WORKBOOK & PROGRAMME

NATO ADVANCED STUDY INSTITUTE

"NEW DIRECTIONS IN TERAHERTZ TECHNOLOGY"

Chateau de Bonas, Castera-Verduzan, France June 30th- July 11th 1996

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PREFACE

The Workbook contains copies of Viewgraphs kindly provided by Speakers before the meeting, together with Extended Abstracts and other materials.

The Edited Proceedings of this ASI will be published in due course by Kluwer as part of their NATO ASI Series.

We are most grateful to the following companies and organisations for their generous financial support and sponsorship of this meeting:

North Atlantic Treaty Organisation
European Research Office of the US Army
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National Science Foundation (USA)
Hughes Electronics
URSI
Daimler-Benz
The University of Leeds
The University of Nottingham

(List dated: June 8th 1996)

The Organisers also wish to add their thanks to the Management of the Chateau de Bonas, to all of the Speakers for their interest in this ASI and of course to all of the Participants for their attendance.

ORGANISING COMMITTEE

Co- Directors: T Itoh (UCLA) & E Kollberg (Chalmers)

J Bowen (Reading): Workbook
J M Chamberlain (Nottingham): Secretary
N Cronin (Bath): Sessions Management
J Leotin (Toulouse): Local Arrangements
R E Miles (Leeds): Proceedings
R D Pollard (Leeds): Treasurer

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PROGRAMME

THEME #1: BACKGROUND AND INTRODUCTION

- "Introduction to Solid State Terahertz Devices- (I&II)" J M Chamberlain & R E Miles
- "Mixers and Multipliers (I&II)" N J Cronin
- "Terahertz Detector Fundamentals" J Leotin
- "Terahertz Receiver Fundamentals" G Beaudin
- "Waveguide and Quasi Optical Measurements" R D Pollard

THEME #2: DEVICE UPDATE

- "Developments in Two and Three Terminal Active Devices" C van Hoof
- "Hot Electron Mixers and SIS Detectors' E Kollberg
- "Schottky Barrier Devices for THz Applications" H-P Röser
- "Device Physics of Intersubband Lasers"
 - P Harrison
- "From Quantum Mechanics to s-parameters" W S Truscott

POSTER#1

- "Travelling Wave Detectors: A new Principle for Terahertz Operation" H Sigg
- "Materials Issues for New Devices"

D Lippens

"P-Ge and P-Si Lasers for Terahertz Applications" T Wenckebach

THEME #3: INTEGRATION

- "Integrated Waveguides and Mixers (I&II)" C Mann
- "Integration of Active Devices" D Lippens
- "Active Antenna Power Combining, Beam Control and 2-D Combining (I&II)" T Itoh
- "Grid Amplifiers"

D Rutledge

- 'System Characterisation Issues for Integration" J Bowen
- "Integrated Antennae (I&II)" G M Rebeiz

THEME #4: APPLICATIONS

- "Astronomy & Atmospheric Physics from Space" T. de Graauw
- "Terahertz Measurements from Satellites"

B Carli

- 'Spacecraft Applications of Terahertz Technology" W J Hall
- "Technical Issues of Terahertz Component Fabrication" R J Wylde
- "Likely Future Instrumentation Requirements at Terahertz Frequencies" D Rytting
- "Potential Applications of Terahertz Systems for Collision Avoidance and Related H Brugger
- "What Future for Wireless Telecommunications Beyond 60 GHz?" D Wake

Panel Discussion

[R E Miles]

"Vector Measurements to 800 GHz"

Presentation and Visit to MATRA Satellite Integration Facility, Toulouse. (F Baudis and S Flamenbaum

THEME #5: LIGHTWAVE/TERAHERTZ INTERACTION

"Lightwave/Terahertz Interaction: An Overview of the Field (I&II)" H R Fetterman

"Optical and Electrical Generation of Terahertz Pulses and Imaging Techniques (I& II)" H Roskos

POSTER #2

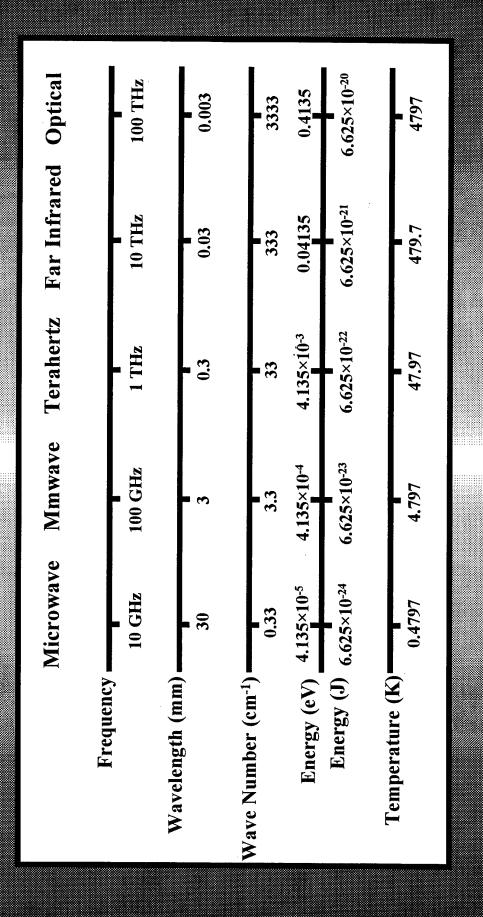
"Multi Gigaghertz Optoelectronic Devices (I&II)" C Ironside

CLOSING SESSION Co-Directors

	0830 - 0945	0945 - 1100	ООГГПП	1130 - 1245	L N S H Ipm	1445 - 1600	T E	1630 - 1745	D N N N N N N N N N N N N N N N N N N N	SUNDAY EVENING: INTRODUCTION FROM CO- DIRECTORS
MON JULY 1ST	Chamberlain [Theme #1]	Miles		Cronin (1)		Cronin (2)		Leotin		Reception
TUES JULY 2ND	Beaudin	Pollard (1)		Pollard (2)		Van Hoof [Theme #2]		Kollberg		Talk by Mme Simon
WED JULY 3RD	Roser	Harrison		Truscott		Poster #1		VISIT TO DISTILLERY	STILLE	ЯY
THURS JULY 4TH	Sigg	Lippens (1)		Wylde	Photographer	Theme #3 Mann (1)		Mann (2)		
FRI JULY STH	Lippens (2)	Itoh (1)		Itoh 🗷		Rutledge		Bowen		ASI Dinner
SAT JULY 6TH	Rebeiz (1)	Rebeiz (2)		de Graauw [Theme #4]		Carli		Hall		Jazz Concert
SUN JULY 7TH	OUTING TO C	OUTING TO CARCASSONNE	E							
MON JULY 8TH	Wenckebach	Rytting		Brugger		Wake		Panel Discussion [Miles]		Visit to Foie Gras Restaurant
TUES JULY 9TH	Goy 9.30 - 11.30	y 11.30			SCIENTIFIC	SCIENTIFIC VISIT TO MATRA	IRA			
WED JULY 10TH	Fetterman (1) Theme #5	Fetterman (2)		Roskos (1)		Roskos (2)		Poster #2		
THURS JULY 11TH	Ironside (1)	Ironside (2)		Closing: Directors						

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Frequency Spectru



INTRODUCTION TO SOLID STATE TERAHERTZ DEVICES

J M Chamberlain*, R E Miles#, C E Collins# & D P Steenson#

Department of Physics, The University of Nottingham, Nottingham NG7 2RD, UK "Department of Electronic and Electrical Engineering, The University of Leeds, Leeds LS2 9JT, UK

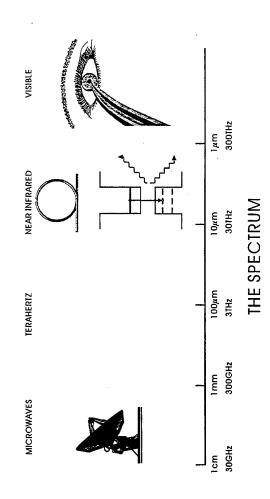




BACKGROUND: OPPORTUNITIES AND PROBLEMS.

PLAN OF TALK:

- Background: Opportunities and Problems
- General Device Characteristics
- Fundamental Sources: Gunns and IMPATTS; HEMTS and HBTs; DBRTDs; Josephson Devices; Intersubband devices.
- Frequency Multiplied Sources: Schottky diode; DBRTD; QBV.
- Conclusions



100 GHz - 3THz: "TRADITIONAL" APPLICATIONS

- Solid State Spectroscopy (useful $h\nu \approx \text{few}$ meV)
- Astronomy/Aeronomy
- Plasma Diagnostics

WIDE BANDWIDTH

Communications:

Global transmission of multimedia

LANs (with Optical Spine)

Digital Applications

WHAT OTHER APPLICATIONS?

RELEVANT PROPERTIES:

- \odot High frequency \Rightarrow Wide bandwidth
- \odot Short wavelength \Rightarrow High resolution

HIGH RESOLUTION

Radar - smaller antenna $[P_r \propto A^2/\lambda^2]$ - short range in atmosphere.

Sensing - e.g. gases: chemically - specific absorption

Imaging

Medical Uses - non invasive, mobility aid

WHAT ARE THE REAL PROBLEMS?

- Emphasis switches from detection to generation: lack of convenient, low cost, solid-state power source.
- Cost & difficulty of producing conventional waveguides & other components.

CONVENTIONAL
(FUNDAMENTAL)
SOLID STATE
SOURCES (OMITTING
DBRTD AND p-Ge LASER)

1000

LASER

<u>.</u>

Output Power (watts)

.001

BUNN

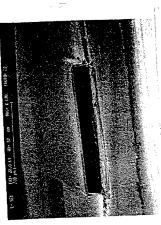
10⁻² 10⁻¹ 1 Frequency (THz)

10-3

CONVENIENT SOURCES MUST INTEGRATED

BE





200 GHz Waveguide 600 GHz Waveguide

GENERAL DEVICE CHARACTERISTICS

ELECTRONIC SOURCES

Two types:-

- ("electronic devices" e.g. FETs) Transit time devices
- Electron transition devices (e.g. diode lasers)

WHY TERAHERTZ GENERATION IS DIFFICULT

1) Transit Time Devices:-

For an f_r of 1 THz, device length < 0.01 μm also power falls as 1/f2

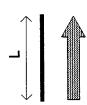
quantum transport, DBRTD

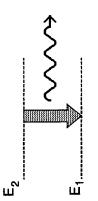
2) Lasers:-

thermal energy at room temp $kT \approx 25 \text{ meV}$ At 1 THz photon energy $hf \approx 4 \text{ meV}$

separate energy levels in real and momentum space, intersubband laser

GENERATION TERAHERTZ





Transit Time Device

Energy Transition Device

In Electronics - Two Kinds of Device

PASSIVE DEVICES

(Power Dissipated)

- r Wave Guide
- Quantum Varactor Diode Resonant Tunnelling Diode

ACTIVE DEVICES (Power Added)

- er Gunn Diode er Impatt Diode er Resonant Tunnelling Diode
- F HEMT (High Electron Mobility Transistor)
- ar HBT(Heterojunction Bipolar Transistor)

 R Superconducting Josephson Junction

Signal processing e.g. frequency conversion, mixing Signal transmission

Used to generate power i.e. sources

High Frequency Figures of Merit

CUT-OFF FREQUENCY fr:-

(i) Passive Device

Frequency where function of the device becomes swamped by the parasities

(ii) Active Device

Frequency where the short circuit current gain becomes < 1.

MAXIMUM FREQUENCY OF OSCILLATION fmax:-

Frequency where the power gain becomes < 1

CUT-OFF FREQUENCY

For a carrier velocity v and device length L then the limiting or cut-off frequency $f_{\rm T}$ is such that the phase change of the applied signal as an electron transits the device is small i.e.

$$2\pi f_T \tau = 2\pi L/\nu \le I$$

or

$$f_T \leq v/2\pi L$$

GENERAL CONSIDERATIONS

a) Transit Time Devices

Frequency of operation determined by the time τ taken for current carriers (usually electrons) to transit the device.

e.g. the drift region of a Gunn or Impatt

under the gate of a FET

across the base region of a bipolar transistor

For high frequency operation we need:-

short length devices fast carriers - saturation velocity ν_s

4114

maximum voltage V_m across a device of length L is

$$V_m = E_B \times L$$

 $E_{\rm B}$ is the breakdown field - depends on the material and the doping level.

Multiplying $V_m = E_B \times L$ and $f_T = v_S/2\pi L$

$$V_{M}f_{T}=v_{S}E_{B}/2\pi$$

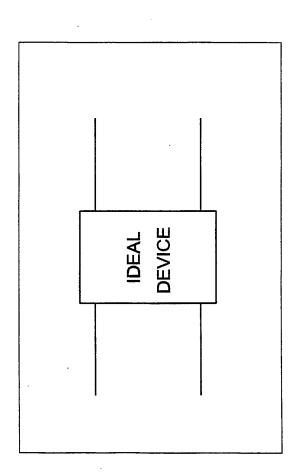
The power P delivered to a load resistance R is given by

$$P = V_M^{2}/R$$

which can then be written as

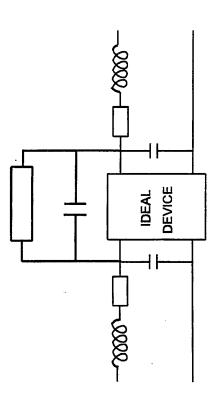
$$P = I/R(v_s E_B/2\pi f_T)^2$$

$$P \propto I/f_T^2$$



GENERAL CONSIDERATIONS (b)

- ♦ Devices are not "ideal"
- there are always parasitic elements
- these become particularly important at high frequencies



In Electronics - Two Kinds of Device

PASSIVE DEVICES

(Power Dissipated)

- F Wave Guide
- Schottky Diode
- 🖛 Quantum Varactor Diode
- Resonant Tunnelling Diode

ACTIVE DEVICES (Power Added)

- F Gunn Diode
- Resonant Tunnelling Diode F Impatt Diode
- HEMT (High Electron Mobility
 - Transistor)
- ₩ HBT(Heterojunction Bipolar Transistor)
 - F Superconducting Josephson Junction

e.g. frequency conversion, mixing Signal transmission Signal processing

Used to generate power i.e. sources

GUNN DIODES

- Utilises the current-voltage characteristic of the 3-5 semiconductors.
- source Useful millimetre wave particularly InP ~ 100 GHz.
- Frequency multiplication to THz range

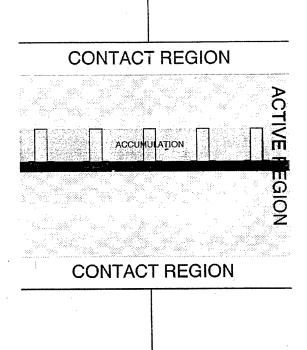
FUNDAMENTAL SOURCES - GUNN AND IMPATTS.

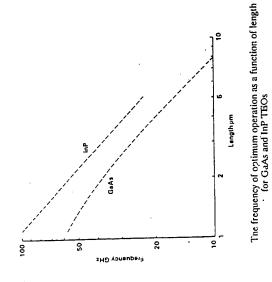
GUNN DIODES

Materials must exhibit the transferred electron effect

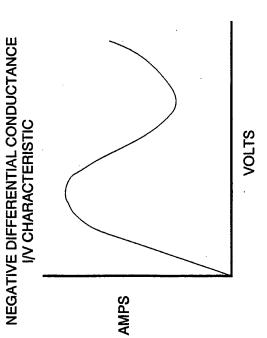
GaAs InP Si won't work

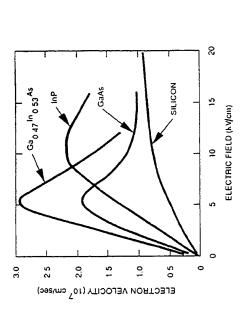
can be used as harmonic oscillators

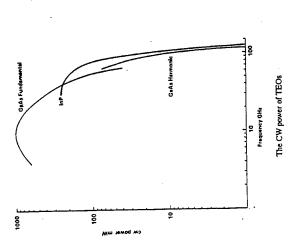


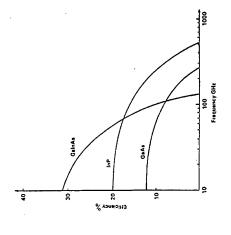


Velocity-Field characteristics of Ga_{0.47}In_{0.53}As, InP and Si.

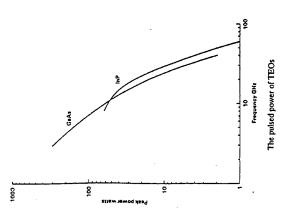








The predicted efficiency of TEOs



IMPATT (Impact Avalanche Transit Time) Diodes

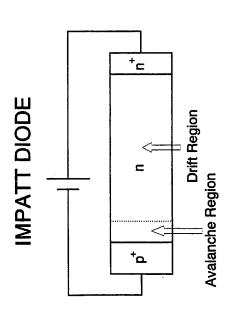
Avalanche breakdown occurs in a high field region at one end during peak of applied voltage

Charge produced travels along a drift region to produce a current that is out of phase with the applied voltage

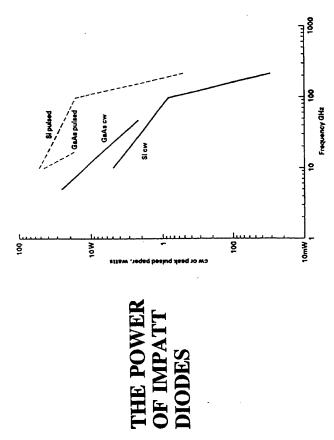
Result - negative resistance

Length of drift region determines the frequency

Can be made in Si and GaAs



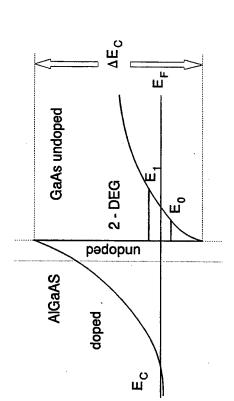
FUNDAMENTAL SOURCES - HEMTS AND HBTS



BASIC HEMT STRUCTURE



HEMT Conduction Band



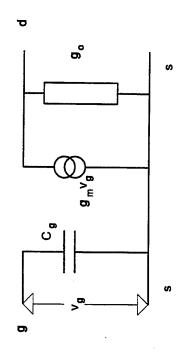
PHEMT CRYSTAL STRUCTURE

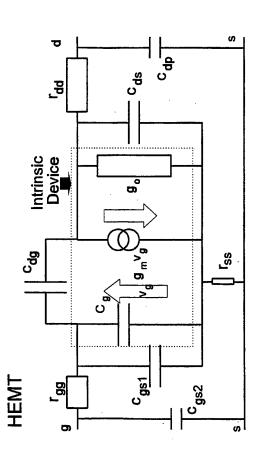
PSEUDOMORPHIC HEMTS

Superior transport properties and narrow band gap of InGaAs GaAs based PHEMT InGaAs/AlGaAs narrow gap/wide gap InP based PHEMT GaInAs/AlinAs narrow gap/wide gap Included as a non lattice matched 2-D electron channel. **ADVANTAGES**

- \odot Larger ΔE_c giving better carrier confinement \odot Higher mobility reduces parasitics
 - \odot Higher peak velocity higher f_T and g_m

Intrinsic Device HEMT





TYPICAL VALUES FOR PSEUDOMORPHIC HEMT EQUIVALENT CIRCUIT ELEMENTS

0.15 micron gate length 50 micron gate width

$$g_m = 100 \text{ mS}$$
 $c_g = 66 \text{ fF}$

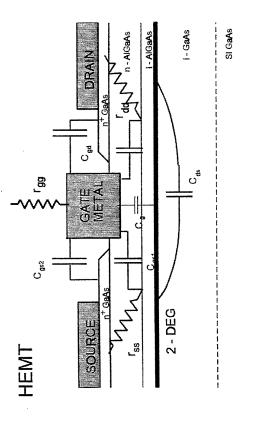
 $c_{d_R} = 7 \mathrm{ffF}$

$$g_{\theta} = 10 \text{ mS}$$

 $c_{21}=100~{\rm fF}$ (relates imaginary part of output current to input voltage)

$$r_{ss}=2\,\Omega \qquad r_{gg}=4\,\Omega$$

$$f_T = 241 \text{ GHz}$$
 founced from 537 GHz to 408 GHz by parasitics



Dimensional Scaling in HEMTS

To maintain an acceptable geometry for the electric field under the gate and hence charge control in the channel

i.e. an aspect ratio of 5

For 0.05 μm device, $L_C \approx 100 \text{Å}$

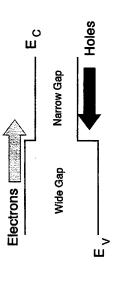
Can make the channel sensitive to surface processing.

Distributed Effects

As wavelengths become comparable to the lateral dimensions of the device distributed effects become important

e.g. In a HEMT the voltage can vary significantly across the gate WIDTH. This limits the finger size so devices must become multifingered

Heterojunction Energy Band Diagram



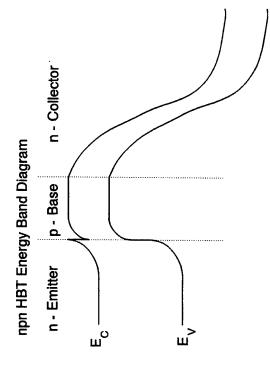
HEMT PERFORMANCE

ræ 0.05 micron InP based devices

ref $f_T \sim 300$ - 350 GHz

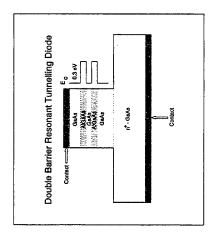
is $f_{MAX} \sim 255$ GHz (target 800 GHz)

Fig. 10 μ W 155 GHz, 2 μ W 213 GHz (Gate width = 10 micron)



FUNDAMENTAL SOURCES

- DOUBLE BARRIER RESONANT TUNNEL DIODE (DBRTD)

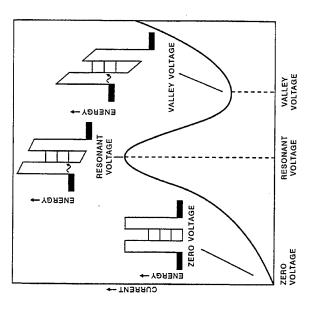


DBRTD

- "Fastest electronic device": operates to 712 GHz
- Realised in : GaAs/AlGaAs, InAs/AlSb
- Characteristics can be "tailored": mixer, multiplier etc

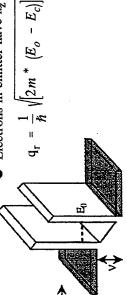
■ Weak device, but power-combining and integration possible

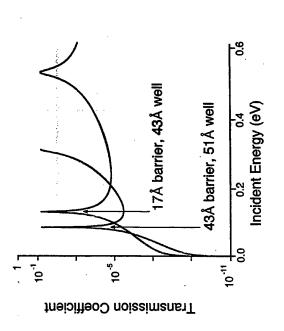
- Operation frequency is not determined "geometrically"
- Building-block for other analogue and digital devices



DBRTD PHYSICS - KEY POINTS (1)

- Energy and momentum parallel to barrier are conserved
- Electrons in emitter have $k_z = q_r$;





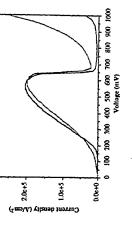
DBRTD PHYSICS - KEY POINTS (2)

- Global Coherent Tunnelling: electron phase coherence unbroken
- Transfer matrix calculation for transmission coefficient of single and double barrier
- Eventually obtain Breit-Wigner transmission

$$T_{tot} \propto \Gamma^2 / [\Gamma^2 + (E_z^2 - E_o^2)]$$

DBRTD PHYSICS - KEY POINTS (3)

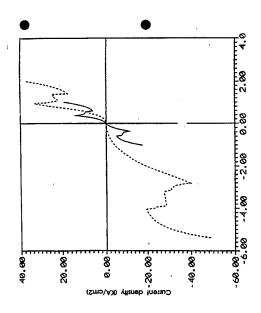
- From T_{tot}, calculate device current
 - $J = \int T_{tot} (E_z) S(E_z) dE_z$
- S(E_z) is supply function, involves: emitter and collector Fermi levels Temperature, m etc.
- Fold-in effects of electronic charge on potential profile.



GROWTH BY MBE

- Molecular beam epitaxy is key technique
- Interface quality of supreme importance (3Å or less steps)
- Technique delivers required layer properties

DBRTD CHARACTERISTICS



Anti symmetric

(suppress even harmonics and subharmonic mixers $(f_{IF} = f_{sig} \pm 2f_{LO})$ for harmonic multipliers

Asymmetric

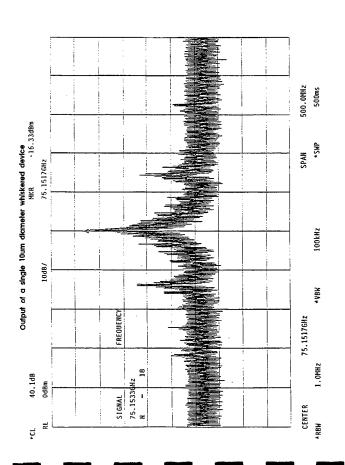
for SOMS, Oscillators

LAYER STRUCTURE FOR NU-366

WHISKER MOUNTING

ı	
0.4µm, GaAs (2*10 ¹⁸)	
17Å, GaAs (U.D.)	
17Å, AlAs (U.D.)	
43Å, GaAs (U.D.)	
17Å, AlAs (U.D.)	
17Å, GaAs (U.D.)	
1500Å, GaAs (5*10 ¹⁶)	
2μm, GaAs (2*10 ¹⁸)	_
GaAs (N ⁺)	

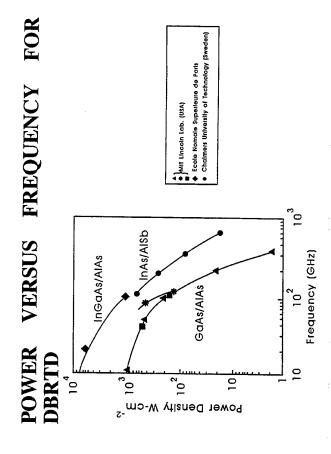
	>5%) essential - limit	
ı) essenti	
ı	ses (> 5 %	
	y of devic	lication?
	Reproduceability of devices (>	to industrial annlicat
	Reproc	to indu



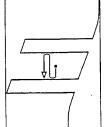
OSCILLATOR PERFORMANCE LANDMARKS

- 2GHz 20 mW GaInAs/AlAs (50% conversion)
- 90 GHz 60μw GaAs/AlAs
- 420 GHz 0.2μ w GaAs/AlAs
- 712 GHz $0.3\mu w$ InAs/AISb

VIDEO OF FREE-SPACE TRANSMISSION

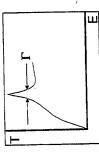


DBRTD FREQUENCY LIMITS



• Intrinsic lifetime $\tau_i = \hbar/\Gamma$ $\approx 100 \text{ fs}$

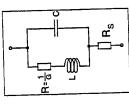
(10Thz)



• Depletion region transit time, τ_d = $d/v \approx 10^{-7}/10^5 \approx 1$ ps (1THz)

• "RC" / time,
$$\tau_{RC}$$

 $\approx \text{CV} \{\text{R.R}_{\text{s}}\}$
 $\approx 2 \text{ps (0.5 THz)}$



MORE POWER FROM A DBRTD (1)

- Individual design: thin barrier, correct depletion length, area, well-width
- [GaAs/AIAs: $R_s < 5\Omega$; C < 100 fF; J $> 10 kA cm^{-2}$; A $< 20 (\mu m)^2$]
- Best material: contact resistance, peak/valley

[GaInAs/AlAs; InAs/AlSb]

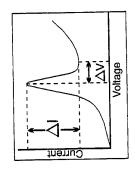
 New design concepts: Schottky collector DBRTD; triple barrier DBRTD; integrated DBRTD and FET

POWER FROM A DBRTD

- Sophisticated large-signal analysis possible
- Small signal approximation

$$P \approx \frac{3}{16} \Delta I.\Delta V$$

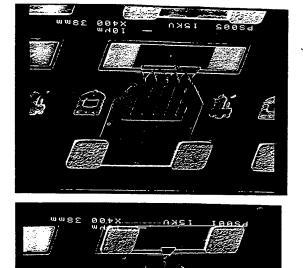
- Increase ΔV with depletion region before collector (trade: C versus R_v)
- Increase ∆I with thin barrier (trade: heating problems)



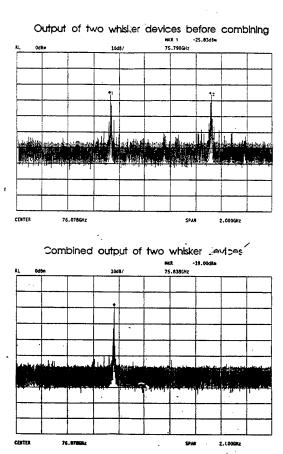
MORE POWER FROM A DBRTD (2)

- Enclosure in quasi-optic cavity ($50\mu w @ 200 \text{ GHz}$: GaInAs/AlAs device: Brown, 1993)
- Series (Boric-Lubecke, 1995) and Parallel connected DBRTDs (Stephan, 1992); Synchronisation problems, perhaps RF excitation.
- Whisker and planar-mounted waveguide combining proof-ofprinciple demonstrated (Steenson, 1994: 12.6μw versus 2.6μw @ 120 GHz)

DBRTD POWER-COMBINING VIDEO



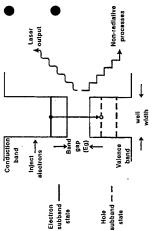
Frederica



The Resonant Interband Tunnel Diode (RIT)

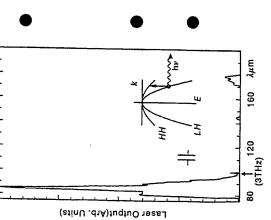
- RITs have been made of broken bandgap materials (InAs/GaSb), InGaAs/AlInAs double QWs in pn structure, GaAs/AlAs QW in pn structure....
- \bullet Large Peak-to-valley ratio exhibited (>100 at room temperature (Day et al., J Appl Phys., 73 1993; InGaAs/AlInAs device) and high current densities (>10⁵Acm⁻²)
- Subtle differences between IV for RTD and RIT arising from different transport mechanisms.
- Much greater device capacitance (10x for similar size device)
- Device characterisation to 35 GHZ; no useful oscillation reported.

FUNDAMENTAL SOURCES INTERSUBBAND LASERS



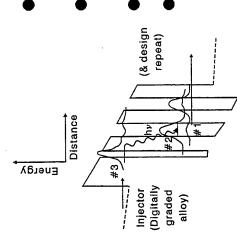
- Bipolar laser unsatisfactory at Terahertz (PbSnTe@10THz)
- Solution may be to use device relying on inter-subband emission:
- (a) hot hole p-Ge laser (Wenckebach)
- (b) Redesigned "Capasso" laser in III-V conductor band. (Harrison)
- (c) hole emission in III-V valence band

HOT HOLE P-Ge LASER



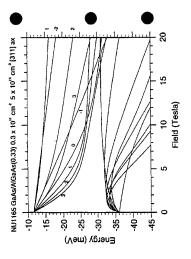
- Population inversion from different hole dynamics of light and heavy holes in crossed E and B.
- 10mW output at 5K with 100W pump.
- "Difficult" device; cryogenic operation.

REDESIGNED "CAPASSO" LASER FOR TERAHERTZ?



- Laser realised in well-controlled material system.
- Subtle well-width design to ensure inversion
- Bonus of $\hbar\omega < \hbar\omega_{\rm LO}$
- More experimental information required

THz HOT HOLE LASER IN P-GaAs/AlGaAs?



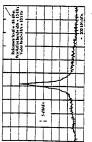
- Hole systems offer great flexibility "any mass or τ you like"
- Parallel Landau levels implies high joint DOS
- Selection-rule breakdown assists output of energy.

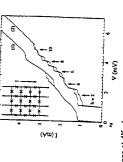
FUNDAMENTAL SOURCES

Josephson Oscillators

- Superconducting/normal/superconducting junctions
- Resistively shunted junction, biased at voltage V, oscillates at:

$$\nu = V/\Phi_0$$
: $\Phi_0 = h/2e$





88 GHz output; 13KHz linewidth; 10x10 array of 4µm Nb/Al-AlO/Nb junctions at 4K (12...

FREQUENCY-MULTIPLIED SOURCES - SCHOTTKY DIODES

Josephson Oscillators

- lacktriangle Phase locked array fabrication possible: power \propto N; linewidth \propto
- High T_c devices reported.
- Performance figures:

Tens of μW at approx. 500GHz - dumped into on-chip resistor [Han, 1994]

 $1\mu \text{W}$ at 110GHz from array - free space propagation [Martens et al, 1993]

- $0.36\mu\mathrm{W}$ at 190 GHz from array-free space propagation [Wengler 1995]
- Although ability to drive mixer has been demonstrated, more promising applications may be digital.

SCHOTTKY DIODE

- Traditional device for THz operation
- Barrier formed at metal/semiconductor function provides desired non-linear characteristic (I-V, C-V)
- Resistive or reactive multiplication possible
- For ideal resistive multiplier, $\eta = n^{-2}$; more complex statement for reactive multiplier; in practice mixed-mode operation
- η in reality dependent on embedding impedances, pump power, I-V and C-V characteristics
- Often run "back-to-back": antisymmetric I-V, symmetric C-V; odd harmonics only.

Ohmic Contact Contact Charact Chottky Contact Chottky Contact Chottky Contact Chottky Contact Chottky Contact

SCHOTTKY DIODE

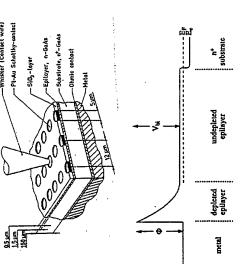
Capacitance at zero bias ~ 20 fF

Diameter $\sim 5 \mu m$

D C series resistance $\sim 10\Omega$

Capacitance swing ~ 2-3

Breakdown voltage ~ 15V



■ Built-in voltage ~ IV

IV

□ γ (doping profile parameter) ~ 0.4

• Depletion region width $\sim 2-5 \mu m$

SCHOTTKY DIODE AS NON-LINEAR DEVICE

$$I = I_o(e^{\frac{qV}{kT}-1}) = 1 + \frac{qV}{kT} + \frac{1}{2!} (\frac{qV}{kT})^2 \cdots$$

 $C = C_0/(V - V_B)^n$

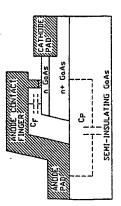
$$V = V_o \sin \omega t$$

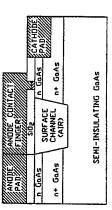
 V^2 terms will give 2nd harmonic (2 ωt)

 V^3 terms will give 3rd harmonic (3 ωt)

PLANAR-SCHOTTKY MULTIPLIERS

- More robust than Whisker contact
- Planar technology appropriate to integration
- Reduce finger-capacitance (size) and pad-pad capacitance with channels, etch-stop layer (lower ϵ) or substrate removal (flip-clip mounting)





OPTIMISATION OF LAYER DESIGN FOR THZ **OPERATION (2)**

- Idea of a "front" between depleted and undepleted regions
- "Front" speed limited by V_{sat} ($\sim 2 \times 10^5 \text{ ms}^{-1}$ in GaAs)
- Start with $t_{epi} \sim V_{sat} / 2f_{pump}$
- Try to maker $t_{epi} \approx W$ (depletion length) at most negative applied voltage
- Then choose doping density just to avoid breakdown (VBr)

$$[V_{Br} \propto (N_{epi})^{-3/4}; W \propto (V_{Bi} + V_{Br} / N)^{1/2}]$$

Then choose anode size to get capacitance right

e.g [Nepi = 2.3 x
$$10^{17}$$
 cm⁻³; t_{epi} = 0.24 μ m; Diam = 2.1 μ m; R_s = 8.50; $C(o)$ = 3.9fF]

OPTIMISATION OF LAYER-DESIGN FOR THZ **OPERATION (1)**

At terahertz frequencies, new effects may be important:

- (1) Similarity in size of anode radius, epilayer thickness, depletion thickness.
- (2) Effects related to plasma resonances (in epilayer)
- (3) Effects related to electron velocity saturation

(1) leads to "edge" effects - new terms in equivalent circuit(2) can be minimised with care(3) probably represents limiting factor to performance. NOTE:

SCHOTTKY MULTIPLIER PERFORMANCE FIGURES

160 GHz input; 4mW 320 GHz output; efficiency \sim 20% [Brickson 1990] Doublers:

160 GHz input; 0.7mW 480 GHz output; efficiency ~ 5% [Erickson 1990] Triplers:

220 GHz Tripler output of 0.7 mW; Planar device;

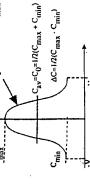
[Choudhury et al 1995] efficiency ~ 7%

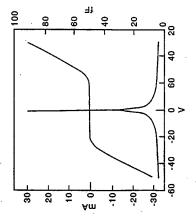
250 μ W at 800 GHz from tripler (3% efficient) [Crowe et al, 1996] Record (?):

FREQUENCY - MULTIPLIED SOURCES - QUANTUM BARRIER VARACTORS AND DBRTDs

THE QBV: A LITTLE DEVICE PHYSICS

- lacktriangle Aim is to produce good capacitance swing: analysis indicates best multiplication for $C_{max}/C_{min} \sim 2-3$
- Also aim to minimise R_s and keep device current low.
- Barrier width increase[™] bigger C_{max}; wider depletion regions
 [™] smaller C_{min}
- Barrier doping increases C_{max}, but may increase current.





Top contact 4000Å GaAs:5×10¹³cm⁻³ Depletion 4000Å GaAs:(undoped) Barrier 50Å GaAs:(undoped) 50Å GaAs:(undoped) 50Å GaAs:(undoped) Buffer 10000Å GaAs:2×10¹¹cm⁻³ Substrate n⁺cm substrate

QBV

▶ Device with antisymmetric IV, symmetric CV
 ▶ Only odd harmonics generated:

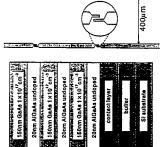
eg 5x, need only one idler.

- Device works with (AlGaAs) Barrier, prevents electrons passing.
- Depletion region at one side, voltage-dependent width & CV
- Limiting factor to power-handling: avalanche breakdown.

THE STACKED QBV

- ◆ To obtain large cut-off frequency, need small C_{min}
 ~ small device, limited output power
- Concept of stacked devices to improve power handling and increase cut-off frequency.

eg Liu et al 1993: 3000 device array, 4x $20\mu m^2$, $f_{co}=150 {\rm GHz}$, output power of 1.25W at 99GHz



PERFORMANCE OF QUANTUM BARRIER VARACTOR DIODES (QBV)

FREQUENCY TRIPLING (x3)

≈ 1 mW AT 225 GHz, 5% conversion efficiency but down to 0.2% at 310 GHz (Rydberg et al 1990)

FREQUENCY QUINTUPLING (x5)

- ≈ 0.1 mW at 172 GHz, 0.78% conversion efficiency (Räisänen et al 1995)
- © up to 20 mW and > 45% and 186 GHz predicted for "Stacked Heterostructure Varactors" in an optimised system.

CONCLUSIONS

QBVs As Multipliers

- Little activity now on this device: QBV (or VHV) probably better bet.
- Anti symmetric characteristics can be tailored for this application
- \bullet Most recent data appear to be for tripler at 257 GHz: efficiency \sim 1%, input power 30-40 mW (Chalmers Group)

TERAHERTZ SYSTEM REQUIREMENTS

For electronic systems we need:-

- \$ sources
- ☆ detectors
- ☆ multipliers
- ☆ mixers
- ☆ amplifiers

SOURCES: Need ~ 1mW across the range LO pump and free space transmission

HEMT: 800 GHz predicted but very low power.

DBRTD: lacking in power.

Inter-subband laser: could this save the day?

Gunns and multiplication. Best bet?

MULTIPLIERS:

QBV looks good - especially stacked

DETECTORS:

Schottky Diodes - OK

Single and Double Barrier Diodes
Not yet proven but probably OK

MIXERS:

Schottky diodes

DBRTD

QBV

all with multiplied Gunn LO

AMPLIFIERS:

HEMTS up to 800 GHz?

DBRTD reflection amplifiers - low power?

INTER-SUBBAND LASER amplifiers?

Mixers and Multipliers

þ

N J Cronin

School of Physics University of Bath

MICROWAVE MIXERS

BASIC PRINCIPLES

The function of a mixer is to voluce the frequency of a signal by beating (or mixing) it with a second locally generated signal from a Local Oscillator (1.0.).

Mixing takes place in a won-linear device—any won-linearity will do in principle e.g. consider a square law device. I.e. owe in which

7/x = I

Suppose that we apply a voltage given by:- $V = V_s (\omega(w_s t) + V_o (\omega_s (w_{Lo} t) + V_$

The resulting current in the device is:- $T = \alpha \left(\frac{1}{5} \ln(\omega_s t) + \frac{1}{10} \ln(\omega_b t) \right)^2$

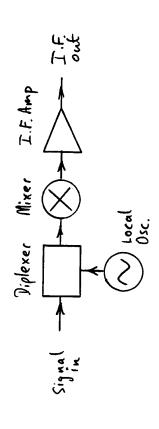
expanding this expression gives:

 $I = \alpha \left\{ V_s^2 + V_{L_0}^2 + V_s^2 \cos(2\omega_s t) + V_{L_0}^2 \cos(2\omega_t t) + V_{L_0}^2 \cos(2\omega_t t) + 2 V_s V_{L_0} \cos\left[(\omega_s + \omega_{L_0}) t \right] + 2 V_s V_{L_0} \cos\left[(\omega_s - \omega_{L_0}) t \right] \right\} / 2$

Note: The non-linearity of the device has produced currents at frequencies other than the two driving frequencies w_s and w_{to} .

In particular the frequency w_s-w_{to} is called the intermediate frequency (T.F.) It is this component which is usually considered to the output from the mixer.

A basic heterodyne downconverter using the mixer would be:-



The differer is a device which overlays the signal and local oscillator before they enter the mixer. The I.F. amplifier amplifies outh the I.F. rejecting all high frequency components such as (0s(2wst) etc. as well as D.C. terms.

If the amplitude and place of the 6.0, are legat fixed then the I.F. output contains all the amplitude/phase information in the signed.

Hixer Noise Temperature and Conversion hoss

The two parameters used to characterise the performance of a mixer are the Norse TEMPERATURE To and the CONVERSION LOSS Lo

If we consider a resistor at temperature T the available voise power per unit handwidth at its terminals is given by:-

Using this any component generating white noise can be assigned a temperature by dividing the noise power per unit bandwidth by Beltzmans Constant.

Consider wow a woisy two-post device connected to a matched source and load: -

The voise per unit bandwidth delivered to the load R is the noise generated by Rs nultiplied by the gain of the two port 9 plus the woise generated by the two post itself kT. Thus

The Noise Temperature of the twoport is defined by reference to an equivalent. Noise 1655 hope port: -

K, & T, =0 - 3 R.

The power delivered to the load is now given y:-

P = R G T

If this is the same as previously:- $\frac{1}{4} \int_{S} \int$

The moise temperature of the two-port is defined as the increase in 1s required is. $T_N = T_0$ $A = T_0$ $A = T_0$

[Nok: To may not be the physical bemperature of the two post — it depends on the two processes involved]

Noise Temperature of an Attenuator

If the two post is simply an alternative than the total noise power into the load

is given by $R[GT_S + T_{A_0}]$. However, an attenuates can be thought of as a returnt

alternatures can be thought of as a natural of hesistas, which can be combined with R, to give an equivalent resistance, still

at temperature Ts (since there are no additional e.g. at 290 K a 10 dB attenuated has a

at temperature Ts (since those are no additioned to isse sources in an alternation) Thus the power into the load is simply to Ts. Thus:

RTS = R[GTS+TA]

TA = Ts (1-9)

from (A) whose

Thus

or waing L= 1 and Is=T in this case

e.g. at 290 K a 10 dB alternative has a noise temperature given by 290(10-1) = 2600 K

Retaining to the simple mixer downconverter

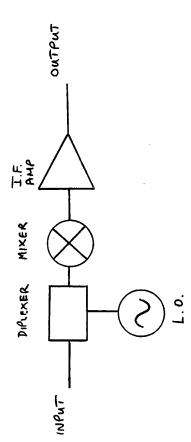


fig = Loral Oscillator frequency

fr = Centre frequency of the J.F.

Af = bandwidth of the J.F. amp.

There are two imput bands which will produce that frequencies with the L.O. which tall within the pass band of the I.F. Amplifier. There are called the signal and image sidebands

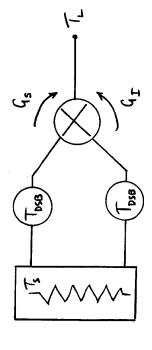
[which is the signal and which is the image depends on how the mixer is being used]

The fact that there are two input bounds but ouly one output band couplicate the definition of the woise temperature of this system— do we assign the noise gowershed in the mixer to one, a both, of the input sides bounds?

Schematically:-

1 - Lssa - Lssa

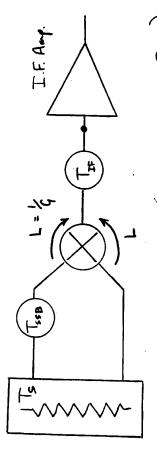
All mixar noise assigned to one side band



Mixar moise assigned to both sidebands

In fact, most mixers exhibit boso rather than gain. This is called Conversion bass and is given by

If we again consider a simple system:—



(baing SSB Noise Temp.)

The noise power into the I.f. Amplifiac is given by:

Subtracting the moise due to the source alone and dividing by Boltzmans bustant and the 'gain' of the mixer gives the single sideband noise temprature of the system:—

or, in terms of the convenion loss:

Components following the I.F. amplifies howe little effect rince their woise contribution is divided by the large gain of the I.F. Amplifier

[Note, here I have included the loss of the diplexer in with that of the mixer—also I have assumed that there is no pre-amplifier between the source and the mixer—always the case of teraherts frequencies]

With these provisions we soo that the system noise lemperature is dominated by three facton: Hixer Noise Temperature

Aixer Conversion hoss

I.F. Amplifier Noise Temperature

QUESTION: Why is system noise temperature important.

ie. if you double the system temperature it takes four times as long to got the same

defectable power level in a given integration time.

In RADIOMETRY the signal are themselves noise and can be Characterised by a temperature. The Minimum defectable temperature by a temperature by and system beaving violise temperature. Tsys and brandwidth. By in an integration time T is squared by:

- This = Tsys - the Radiomek

JANT - Equation

Equation

DIODE MIXER THEORY

The analysis of a diode mixe proceeds in three phases:- The voltage and Current waveforms produced in the diode by the Local Oscillator are determined using non-linear circuit analysis

Small signal analysis is then performed to obtain the mixer input and output impedances and the convenion loss.

shot noise components produced in the diode are defermined and the mixer noise temperature calculated. Down converted themal and

Before proceeding we need to devide a few ideas concerning transmission lines and

impedance -

Fransmission Lines

The parallel wine transmission line consists how were aming parallel to each other with the spacing small compared to the wavelength. A Swint (v)

If an oscillator is connected, as above, a wave will run about the line to the right. If we now terminate the line in an impedance in general, there will be a uflected wave waving to the Self:

Kerlected INCIDENT |

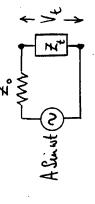
Every transmission live has a characteristic Impedance Z, if Zt = Z there is no Meded wave. The transmission live is then said to be matched.

All prevailing anditions repeat every wavelength.

about the line. Thus if a line is an Inlease and impodance are the same at toth ends.

Thus, at a fixed frequency are can insert sad a length of teausmission line without any year or a circuit.

As far as the termination is concerned the subtration is:-



ie the transmission line looks like a source with output injedunce to

Note: if Zt=Zo then 1/2- Alinwt

Thus, the voltage produced at the femination by a wave travelling to the right is half of that produced by the source.

EMBEDDING IMPEDANCE

The operation of the wixer is dependent found the electromagnetic environment in shich the dide finds itself. For our purpose this is characterised by ENBEDDING IMPEDANCES.

These can be delined as follows: -

Actual Mixer Inaginary

The timy oscillation oscillates at the frequency of interest e.g. signal, 1.0. oft.
The oscillation causes corrects to flow into the

The oscillator causes current, to flow into the terminals where the diode was located Into the applied rollage is just then the embedding impedance at frequency is:—

 $Z_{e}(\omega) = V_{e} j \omega R_{e}$

The value of Ze (w) depends upon the physical structure of the nixo e.g. whisher length, trackshort position of c.

Enbedding impedances may be defermined by measurements on scale models, from equivalent circuit models or computer modelling of the electromagnetic field (HFSS etc)

77

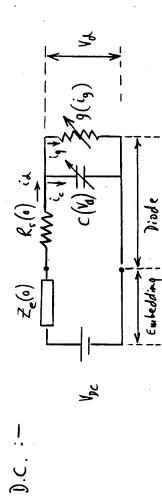
- · determines the voltage and accreat waveforms produced at the diode by the Local Oscillator.
- Harmonic Balance Technique

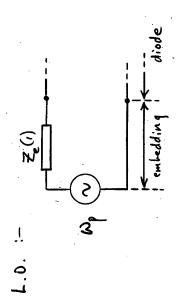
Harmonic 1Wp:

Wass the Time Domain when considering the diode and the frequency bomain whethere embedding circuit. considering

Large Signal Equivalent Circuit :-

the mixes at D.C., the local oscillator frequency We need an equivalent circuit which represents and all of it's harmonics:





embedding

The first step is to express Vy and is as Fauriar Series: -

$$V_{d}(t) = \sum_{\Lambda=0}^{\infty} V_{d_{\Lambda}} e^{J_{\Lambda} M_{\rho}} t$$

$$V_{d}(t) = \sum_{\Lambda=0}^{\infty} T_{d_{\Lambda}} e^{J_{\Lambda} M_{\rho}} t$$

denive the Following constraints on Vg, and Id: - evaluedding network) and the embedding network. From the equisablent circuits we ran now

$$V_{L0} - V_{d_1} = Z_{e(1)} + R_{s}(1)$$
 [.0.

$$\frac{-V_{dn}}{\pm d_{n}} = \frac{Z_{e}(h) + R_{s}(n)}{\pm R_{s}(n)}$$
 Harmonic

Once we have the correct solutions for va(t) and id(t) the fourier components will satisfy the equations.

Multiple Reflections

We wow introduce an imaginary transmission line between the intrinsic dioda (dioda In the method of Held and Kerr

monus Rs - which is lumped in with the

This hansmission line is an integer member of wavelength long at the 6.0. frequeng -

det the characteristic impodance of this line he Z. (arlitray)

and Is should be equal at all the frequencie wowe, at all the harmonic frequencies, transling Because of the bugth of the line of In operation, at am instant, there will be in the best and right directions.

The total voltage and current on the transmission line are given by:-

(a)
$$V(x) = V_r(x) + V_g(x)$$

$$V(x) = V_r(x) - V_g(x)$$

$$V(x) = V_r(x) - V_g(x)$$

live and the 'minus' comes from general transmission Here x is a position wordinate along the line throng.

Because the line is an integer number of

wavelength, long

$$V(x=0) = V(x=l)$$

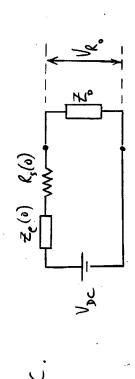
V(x=0) = V(x=-1) (where l=the i(x=0) = i(x=1) (laught of the

We begin the calculation by assuming that

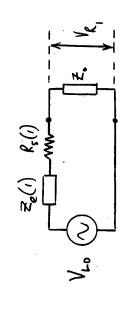
t=0 the dide is nowoned and replaced

by a matched load Z, which genealls wo

by the dieds - we assume that the voltage on the dide is initially as it was with the At too the look is removed and replaced



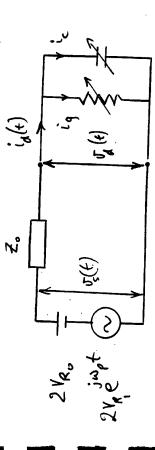
$$V_{R_0} = V_{DC} \stackrel{Z_0}{\longrightarrow} \left[Z_0 + K_s(0) + Z_s(0) \right]$$



$$q) \qquad V_{R} = V_{L0} \frac{z_{o}}{\left[z_{o} + R_{s}(i) + z_{e}(i)\right]}$$

At too there are the ouls voltages, therebox,
the total voltage across the intrinsic diode is:- $\sqrt{\lambda}(t) = \sqrt{\lambda} + \sqrt{\lambda} = \frac{1}{2} \frac{1}{2} \frac{1}{2} + \frac{1}{2} \frac{1}{2} \frac{1}{2} + \frac{1}{2} \frac{1}{2} \frac{1}{2} \frac{1}{2} + \frac{1}{2} \frac{1}{2} \frac{1}{2} \frac{1}{2} + \frac{1}{2} \frac{1$

After councestion this voltage is applied across the diode by the transmission line, the equivalent circuit in the time domain is:-



Note The factor of two desirabled earlier

The state equation for this circuit is:-

$$C(t) \frac{d v_{dk}}{d t} = \left[\frac{v_{s} - v_{dk}}{z_{o}} - i_{g}(t) \right] \qquad (i_{o})$$

Using the diode characteristics this equation can be integrated we were ically giving a first estimate of the diode voltage and cornent waveforms which will use include higher hamonics of the 6.0. Frequency.

Muse voltages now give rise to now left travelling wave or the honemission line. Solving © and Z we can obtain the solutions for such wave from the arrest and voltages at the and of the line:—

$$V_{\{x:e\}} = V_{\underline{a}(t)} - i_{\underline{a}(t)} Z_{o} \qquad (!)$$

This can was the Fourier Analysed to yield an equivalent expression to each of the harmonics

$$V_{L_n} = V_{d_n} - T_{d_n} Z_0 \qquad n = 0, 1, 2...$$

These waves view propagate to the LEFT where they encounted the corresponding Embedding Inspectating a raw set of Right handling wave. The reflection welficiant of the barmonics is given by:—

(3)
$$\int_{R} = \frac{Z_{e}(h) + R_{s}(h) - Z_{o}}{Z_{e}(h) + R_{s}(h) + Z_{o}}$$

Sn= 2t-73 , Zt= terminating impodana

The rew equivalent circuit for the time domain solution at the diade and user

 $2 \left(\frac{9}{2} v_0 + v_0 \right) \frac{1}{4} \frac{1}{4}$ $2 \left(\frac{9}{2} v_0 + v_0 \right) \frac{1}{4} \frac{1}{4} \frac{1}{4}$ $2 \left(\frac{9}{2} v_1 \right) e^{j 2 \omega_0} \frac{1}{4}$ $2 \left(\frac{9}{2} v_1 \right) e^{j 2 \omega_0} \frac{1}{4}$

Equation (12) — the state equation can use be re-solved to give a new solution for iq(t) and va(t)

until equation (5) is satisfied for all the The above procedure is repeated harmonic frequencies: -

$$-\frac{\sqrt{d_{h}}}{\pm d_{h}} = \frac{2}{\epsilon}(n) + R(s) \quad n > 0$$

and equation (4) is satisfied for the 6.0.

frequency:

$$V_{0}-V_{d_{i}} = Z_{e}(i) + R_{s}(i)$$
 $T_{d_{i}}$

The current values of of (+) and in (+) are then taken to represent the true solution.

SMALL SIGNAL ANALYSIS

From the large signal analysis we have determined the amount and woltage waveforms in the diods i.e. we now know Id (+) and V₄ (+) :-

From the known characteristics of the S.B. diode $T_d = T_0 \left[e^{\frac{4V}{4RT} - 1} \right]$

The conductance
$$g = d \pm a$$

4

As we know that 9 must be periodic with the period of the h.O. pump we can express g(t) as a complex Fourier series:g(t) = 2 Gn e in what (2) m=-0

where, tunce g(t) is real, g = g*

Similarly, from the known diode properties and the large sizned analysis we can express the time varying diode capacitance as: $C(t) = \sum_{i=1}^{\infty} C_{i} C_{i} C_{i}$

Where C = C*

As far as the signal is concerned the pumped diode believes as a linear component with time varying conductance and capacitance given by equations (2) and (3)

SMALL SIGNAL HIXING FREQUENCIES

When a signal is applied to a fumped dioda aumunts and voltages are generated at many frequoncies, illustrated below:-

ω_p = ω_p +ω_o (in this example)
ω_p ω_p ω_p 3ω_p ω_o 3ω_o 3ω_p ω_o 3ω_p ω

- Applied signal

Currents and voltager generaled (as well as

The three and not frequencies are alled the small signal mixing frequencies. The pumped divole couples than all together

We can group these together as follows: -

T.F. Upper Sidebands bown Fidebands

Wo + Wo Wo Wp - Wo 2 Wp - Wo 3 Mp + Wo 3 Mp + Wo 3 Mp - Wo 3 Mp - Wo Mp - Wo

the some sidestand frequencies are of the form of the

By examining these phases in detail we can make a useful sumplification. For example consider equation (7) All voltages are advable REAL. Therefore when we write $V_A e^{i(\pi i)p - \omega i}$ we actually mean:-

Va is a complex amplitude, thumper let $V_n = V_n = V_n e^{i(n\omega_p - \omega_n)}$

that :- $\left\{ a \leq V_{n} e^{j(n\omega\rho - \omega_{0})} \right\} = \left\{ a \left\{ v_{n} e^{j\omega} e^{j(n\omega\rho - \omega_{0})} \right\}$ $= V_{n} \left\{ \sigma_{n} \left[n\omega_{\rho} - \omega_{0} + \varphi \right] \right\}$

(lowing las(-8) = las(8) we can re-write this as:-

This function can now be written as $\left\{ \begin{array}{ll} \sum_{i=1}^{n} \beta_{i} & j(\omega_{0} - n\omega_{p}) \\ \lambda_{n} & j \end{array} \right\}$

of in phasos unfation

* j (wo-nup)

If we now define the integers specifying the lower sidelounds to be negative than equation (7) becomes

V* e) (W0+MWp) n=-1,-2,...-0

The I.F. Gregnenay can be written as 1/e

hower wans all of the sidebands fall into

the serio

Where for negative or In is the complex conjugate of the actual take.

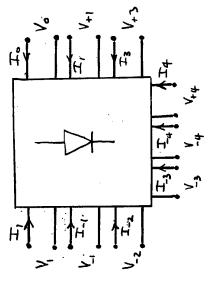
Switanly the diode current can be written:—
j (wo + 11 wp)

The

with In complex conjugated for -ve integers.

The Convenion Admittance Matrix

The pumped dinde can be thought of as a multi-port circuit with one pair of terminals torteach of the mixing frequencies:



+ Many other port:

Note — In practice we only need to consider a finite number of frequencies

The currents and ordhayes in the ports of the intrinsic diode can be represented as let this veryelve be N. a MATRIX equation:-

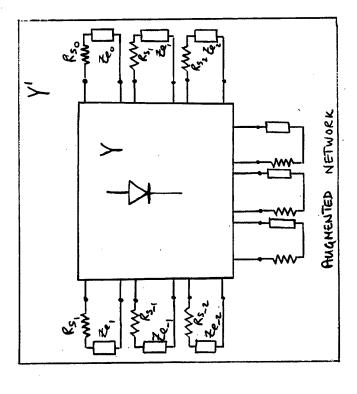
So, if for example we were to short part N of voltages applied to the other parts would be the current which would flow as the routh given by

The Matrix Y is called the conversion ADMITTANCE MATRIX.

We can show that the components of Y are given ly:-

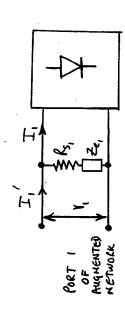
COMPONENTS of the conductance and capacitance 1x Where Gm-n and Cm-n are the FouriER would forms.

The Y-matrix of the intrinsic diode is wow Augmented by connecting the spreading resistance, ks, and the embedding network in parallel with the ports:-



Note: the ports of the Augmented metwork have remained as far the intrinsic diode.

e.g. consider port 1:-



Ry and Ze, are linear and do not add to the the queency conversion process. Therefore applying rollage V, to poit (of the augmented nutronth results in the same currents in all the other ports as generated by the other ports as generated by the other diagonal add the other diagonal abounts of Y' are the same as Y

From the definition of Y $T_i = Y_i, V_i$ The current through R_s and Z_{e_i} is given by $\frac{V_i}{R_s + Z_{e_i}}$

T'= Y, V + V', Z+2

$$T_i' = \left[Y_{ii} + \frac{1}{k_i + k_e} \right] V_i$$

Determination of Conversion hoss

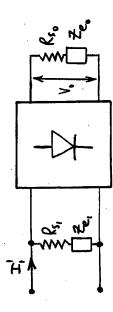
For the augmented network we have the mathix equation

 $(X_{N_{n-1}}, X_{N_{n-1}}, X_$

Inverting equation (8) gives

where Z' = [Y'] is the Augmented conversion in Pedanice intities. From Z' we can delamine the conversion loss.

If we assume that the signal is input to the Wixe at Frequency W, (wp+W.) and the I.F. is oxhaded at Frequency W. there are the outstood ports of interest — the citain is though effectively a two port:—



We exist the mixe by injecting a current into part 1 of the augmented vetwork.

from equation (9) — assuming there are no inputs at other parts

$$V_0 = \stackrel{\wedge}{Z}_1 \qquad (0)$$

The rolling which appears across Ze. — the achul IF. boad impedance is given by:-

The current flowing through Zeo is given by:

The time awage power delivered to teo is given by:- Pe I Re [Ver Ix]

Vous equation (10) This becomes:-

On the input side (Port 1) we can use Theoremins Hubreum to show that:-

$$\frac{1}{T} \left(\frac{1}{T} \right) = \frac{1}{T} \left(\frac{1}{T} \right) = \frac{1}$$

The piwer AVAILABLE from the actual signal So that for the LI (Ze+Rs) I * (Ze+Rs) *]

The piwer AVAILABLE from the actual signal So that for the LI (Ze+Rs) I * (Ze+Rs) *] Lead :-

$$V_{s} = T_{s}(z_{s} + \xi)$$

Vm. = 1 1/5 = 1/2 T/ (2e, + Rs,) The voltage across the matched load is: -

Inc = Vs = I(Ze, + ks) The current is given by:-

.. Power delivered to the matched load in: -Pr = 1 Re [Vac. Int]

the power available from the source divided The conversion loss is now defined to be lloing ") and is) above, we use have the ly the power delivered to the I.F. load.

S 0

MIXER NOWSE ANALYSIS

Sources of noise in a mixer are:

- . Thermal Noise in Rs
- Shot Noise in current through the diode junction
 - lattice scattering noise
- that elactron noise
- . Thermal unise from nosistive elements in the embedding notwork

Vouelly only the first two are considered to be

significant.

The NOISE EQUIVALENT CIRCUIT IN this dave is: -

ENBERDING

NETWORK

NETWORK

LE 4 KT R A L

LE 4 F R

LE 2 G R

LE 4 F R

LE 2 G R

LE 4 F R

LE

These worse courponents appear at all of the 'PBRTS' of the AugmenTED NETWORK. Some of this woise power is converted to the I.F. Frequent where it contributes to the woise temperature of the wixer. Knowledge of the conversion impedent makin 2 enotytes the moise temperature of the wixer to be calculated:

755B = < 18V, 12 > 12e+ Rs, 12 4k Af 120, 12 Re [20,] where $\langle 18V_{N}|^{2} \rangle = \hat{Z}^{1} \left(C_{S} + C_{T} \right) \hat{Z}^{1}$ \hat{Z}^{1}_{S} is the centre row of the Augmented Impedance conversion Matrix

Cs and Ct are matrices representing the and the noise at the mixer output terminals.

Cs and Ct have been evaluated:-

Smr = 29 Im-n bf

where Im-n is the (m-n)th Fourier compount of the diade conductance current (available from the Sage signal analysis)

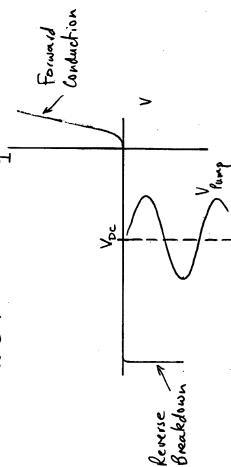
Ctmn = 0 for until

= 4 kT Rsm bf for m=n= | Zem+Rsm | ? 4kT Rs, Af for m=n=0

FREQUENCY MULTIPLIERS

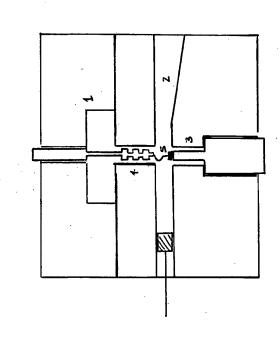
- Use the non-linearity of the S.R. diode to generate harmonics of a pump source provide solid-state L.O. Sources above about 100 9Hz.
- Harmonic generation is fossible through either the non-linear conductance or capacitance of the divola. However, modern nultiplies almost always were the non-linear capacitance of the divola as the main harmonic generation nechanism.
- Diodes ward in multipliers differ from three week in mixen thuy are optimised to give the greatest capacitation possibly. Such diodes are reford to as vARACTOR DIODES

· Varactar diodes are operated under REVERSE BITS to give the best possible capacitance variation and limit the current - thereby increasing the power bandling capability of the device.



In the reverse bias region the depletion layer thickness varies with bias - giving the capacitance variation. The perlayer thickness must be great enough to accompation warriation - therefore vARACTOR diodes have thicker epi-layer than Mixek diodes

(but of course not practically achievable) it may be necessary to allow significant The Analysis of a frequency multiplier urrent flow at the second harmonic into a low loss resonator. This is To achieve the maximum efficiency It can be shown that a numbiplier an example of an IDLER circuit. at the third harmonic, for example, of 100% are throwhically possible house a conversion officiency (PHARMONIC) of at most I where is the harmonic number. Varactor house is - In principle the same as the using a mon-linear capacitance ran no such limitations - efficiencies MRGE SIGNAL analysis of a mixer.



- pump waveguide
- Cooxial resonator, the 2nd harmonic IDLER Filter to prevent 3rd harmonic loss to the pump waveguide 3rd harmonic output wavequide
- The diode
- Moveable tack short (also in pump waveguide not shown)

MULTIPLIER ANALYSIS

24

number of harmonics) and the diode conductance The Frequencies of interest in the multiplier that we know the embedding impedances at harmouries AWD. Once again we assume all 8) than Araquencies (up to a reasonable are the pump Arguencis up and its and capacitance characteristics.

voltage, urrent, capacitance and conductance balance collection to defenine dioda One again we camy out the hamonic ACTUAL DIOTE TERNINALS INTRINSIC Rs, H. wanter >

1st harmonic Power in at

out the j-the bains Power out

N/A

V, , I, , V, and I, are available from the barmonic belong calculation

The pump power 'absoiled' by the diodo is given by:-

The power 'delivered' to the boad impodance \mathcal{L}_{e_j} is given $lugin - \frac{1}{2} Re \left[I_j^* V_j \right] = \frac{1}{2} Re \left[I_j^* I$

= 1/1/2/a[tej]

TUESDAY JULY 2

FUNDAMENTALS OF RECEIVERS FOR TERAHERZ SYSTEMS

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I - INTRODUCTION

The submillimeter wavelength spectral band, covering the frequency range 0.3 THz (λ = 1mm) to 3 THz (λ = 0.1 mm), represents one of the the least explored yet information rich segments of the electromagnetic spectrum. This frequency span encompasses all of the critical spectral emissions from the key molecules involved in atmospheric chemistry on Earth (and on the planets and connets). These include those molecular transitions which have been identified as crucial to our understanding and monitoring of the global conne depletion problem. The submillimeter-wave regime also contains spectral line emissions which can further our understanding of interstellar chemistry, new star formation and galactic structures. Due to high atmospheric opacity (Fig. 1) both astrochemical and stratospheric observations in the submillimeter-wave spectral bands must be made from high altitude aircraft: Kuiper Airborne Observationy (KAO/NASA) and SOFIA; balloons: PIROG (SSC), Programme National d'Astronomie Submillimétrique (PRONAOS/CNES) or

There are three funded space missions which will carry submillimeter wave radiometers: Submillimeter-Wave Astronomy Satellite (SWASNASA), ODIN (Swedish Space Centre, SSC) combining Astronomy and Aeronomy objectives, and Earth Observing System Microwave Limb Sounder (EOS-MLS/NASA). Four other missions are in phase A/B study: the Submillimeter Observation of PRocesses in the Atmosphere Noteworthy for Ozone (MASTER-SOPRANO/ESA) for Aeronomy, ROSEITA for pipateatry and cometary observations, SAMBA-COBRAS for cosmology and the Far-Infrared Space Telescope (FIRST/ESA) for Astronomy.

SWAS has two radiometers at frequencies of 490 and 550 GHz; ODIN has three radiometers, at 120, 480 and 550 GHz; EOS-MLS is currently configured with radiometers at 210, 440 and 640 GHz and potential channels at 1.2 and 2.5 THz. MASTER - SOPRANO is a project having two instruments on 200, 325 and 350 GHz; and 500, 630 and 950 GHz frequency bands; ...

FIRST is designed to have broad spectral coverage beginning at 500 GHz and going up to 1.2 THz.

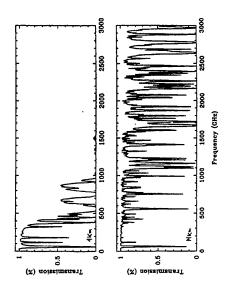


Figure 1: Amospheric transmission in the submillimetre and far-infrared from a very good high-altitude ground-based site (Mauna Kea at 4.1. km with 1 mm of precipitable water vapour) and from the altitude of an airborne observatory (e.g. KAO at 14 km altitude). The blocked regions are mostly caused by molecular absormers.

NATO: Advanced Study Institute new directions in Terahertz Technology, Toulouse, July 1996

II - DETECTION TECHNIQUES FOR SUBMILLIMETER WAVES

There are two basic ways to analyse electromagnetic radiation at submillimetre and far-infrared wavelengths, either by (super-) heterodyne (coherent detection) or by direct (incoherent) detection techniques. This part of the spectrum lies between what traditionally can be regarded as the radio and infrared domains and the two techniques reflect this fact (fig.2):

Direct and Heterodyne Detection Systems

In direct detection (fig. 3) the detectors respond to the signal photons themselves; in heterodyne detection (fig. 4) the signal is converted to a lower convenient intermediate frequency (IF) by "mixing" with a generated stable monochromatic local oscillator (LO) signal before signal processing.

The fundamental difference between the two types of detection is the retention or destruction of the phase in the detected signal. The quantum mechanical uncertainty principle shows that heterodyne detection can never be more sensitive than direct detection, at least in principle. Fixing the phase causes a measurement uncertainty of order one photon in a heterodyne conversion process; this is equivalent to imprecision introduced by a noise source. The lack of phase sensitivity in incoherent detection enables the direct detection of individual photons.

Since instruments based on direct detection respond to signal photons alone, spectroscopy must be done by separating individual frequency components in the incoming signal (fig. 3) before detection. With the exception of Fourier transform instruments, incoherent systems measure one frequency channel per detector, requiring some scanning of the predetection filter to obtain a spectrum. A typical heterodyne receiver consists of two seperate parts: a heterodyne mixer (the "frontend), which shifts a high frequency band of frequencies from one center frequency to a lower one without altering the spectral information within the band, and a separate ("backend") spectrometer which obtains the spectrum of the lower frequency band (fig. 4). Since the spectroscopy is performed at low frequencies, simple filters with modest resolution can be used. The backend spectrometers of heterodyne systems analyze the entire instantaneous receiver bandwidth, which in practical cases will cover the spectral line and baseline. The frequency multiplex advantage of the heterodyne backend can be offset by the simpler spectral or spatial multiplexing of incoherent array elements.

The choice of heterodyne or direct detection for a given application at submillimetre and far-infrared wavelengths is not always obvious, as it is in this range of the spectrum that the two methods both cross in sensitivity and become technologically possible. Tradeoffs, involving for instance observing frequency, spectral and spatial resolution and coverage, required sensitivity and detector availability, will determine whether Fourier transform, grating, Fabry-Pérot, or heterodyne instruments will be best suited to this figure.

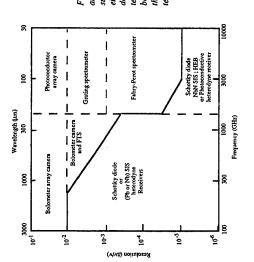


Figure 2: There are two basic ways to analyze electromagnetic radiation at submillimetre and far-ityfracted wavelengths, either by (super-) heterodyne (coherent detection) or by direct (incoherent) detection techniques. This part of the spectrum lies between what traditionally can be regarded as the reduction the though and influed domains and the two therethingues reflect this fact.

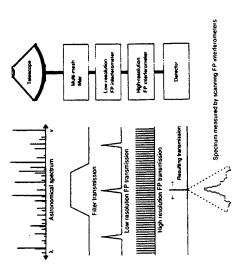


Figure 3: Principle of direct detection system

The spectral bandwidth is reduced by a succession of filers and interferometer's. Approximate wavelength selection is made by means of a bandpass filter isolating one Fabry-Pérot interferometer transmission fringe. By adding one additional interferometer at higher resolution (larger mesh spacing) a final higher resolution is achieved. the transmitted, very narrow bandpass, can be scanned in wavelength by tuning the two interferometers enabling the detectors to sample different parts of the spectrum.

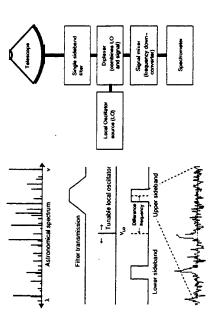


Figure 4: Principle of heterodyne detection system

Downconversion of the received signal to an easier to process frequency is achieved by adding a tuneable line signal (local oscillator) to the received one and extract the different frequency. A filter can be used to select any of the two received sidebands. Signal merging is performed in a diplexer before feeding the signal to the mixer. After further amplification the downconverted signal can be analysed at the chosen frequency resolution in the backend spectrometer. This device samples simultaneously a very large number of frequency channels.

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III · SUBMILLIMETER HETERODYNE TECHNOLOGIES

All of the missions requiring high sensitivity and high spectral resolution use the heterodyne detection technic (fig. 5). Such receivers generally consist of a low loss signal coupling structure (waveguide feed hom of planar antenna), a local source of RF power (local oscillator, L.O.) at a frequency very closed to that the observed signal, a frequency diplexer which efficiency couples the RF signal and LO into the low noise down converting (mixer) element (Schottky barrier diode or SIS superconducting turnel junction), a low noise intermediate frequency (IF) usualy in the microwave band, and finally a high resolution spectrometer to separate out the spectral lines (filter banks, digital autocorrelators, surface acoustic-waves filters, acousto-optic spectrometers), are used.

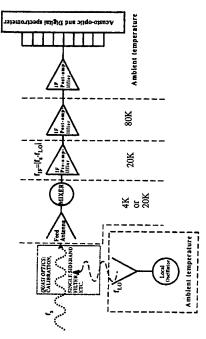


Figure 5 : Schematic outline of a heterodyne receiver

using common quasi-optics and spectrometers. Each channel have SIS mixers operating at 4 K, or Schottky mixers operating between 20 K and room temperature.

· SUBMILLIMETER HETERODYNES MIXERS

Both Schottky diode and superconducting tunnel junction (Superconducting-Insulator-Superconducting = SIS) mixers could be used on the submillimeter heterodyne receivers. The Earth (or other planets) atmospheric research don't need a so high sensitivity, is the more often using Schottky diode mixers; the astrophysic research needed the highest sensitivity, currently employe SIS mixers. Waveguide with hom and Quasi-optical mixer technologies are both employed up to 2.5THz. Arrays have been developped for astronomical focal imagery.

Submillimeter Schottky diode developments

For more than two decades the best uncooled beterodyne radiometers for use in the 100 GHz - 3 THz frequency range thave been composed of waveguide or open structure mixers with whisker-contacted metal-semiconductor Schottky-barrier honeycomb diodes.

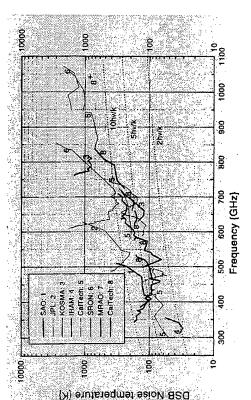
In order to reduce the assembly cost and improve the reliability and reproducibility of heterodyne receivers for the space missions throughout the millimeter and submillimeter wavelength bands, two major changes must be incorporated into current radiometer design. First, the whisker-contact honeycomb diode must be replaced by a more reliable, easier to handle, integrated structure similar to the beam-lead diodes now routinely used below 100 GHz. Second, for applications up to (or above) 800 GHz, the diode must be integrated with the remaining, physically larger, mixer circuitry to increase flexibility and simplify assembly. An added benefit to this latter approach is the potential of going one step further and replacing the last remaining mechanically fabricated component, the waveguide mount, with an all plana photolithographic structure scalable to frequencies well beyond a THz (JPL, SHP mixer at 650GHz). A major goal is to advance the state-of-the-art in millimeter-wave quasi-planar-diode technology to the point at which it can be used readily at frequencies as high as 2.5 THz.

The Schottky diode must be cooled to about 20-30 K for optimum performances, but works even at room temperature.

4

SIS Tunnel junctions developments

In the push to obtain ever higher sensitivity, shorter observation times and the use of smaller collecting surfaces, the submillimeter-wave astrophysics community has devoted much of their ressources towards the developpement of radiometer front-ends based on the refractory superconductors nobium nitride. At present, the most prevalent form of high frequency superconductors yuperconductors nobium nitride. At present, the most prevalent form of high frequency superconducting heterodyne receiver is the small area superconductor-insulator-superconductor NkSIS) turnel junction which offers the potential of near quantum limited sensitivity throughout the millimeter-wave bands up to 700 GHz (fig. 6) and possibly at frequencies as high as 1.2-1.4 THz with normal metal tuning stubs circuits (Al). 2-3THz could be achievable in the near future by using SIS with NbN superconducting junctions or by using Hot Electron Bolometers heterodyne mixers. The SIS mixers must be physically cooled to temperatures well below the superconduction transition temperature, i.e. to 4 K for NbAxQo,l/Nb elements. However, the requirement for a liquid helium ambient environment poses a significant limitation for remote, long lifetime space operation.



Thick lines represent fixed-tuned mixers.

Compiled by SRON, March 19, 1996

Figure 6 : Heterodyne SIS receiver noise temperatures. The currently best experatures. It is estimated that $T_{\rm rec}$ bot obtained receiver noise temperature ($T_{\rm rec}$) vs frequency for SIS mixers. It is estimated that $T_{\rm rec}$ for the 1 THz cooled Schoutky receiver will be approximately 1000 K.

B - LOCAL OSCILLATOR GENERATION TECHNOLOGIES

The L.O. power needed for Schottky diodes or SIS junctions, is currently obtained by Gunn oscillators cascaded with frequency multipliers using whiskered varactor diodes (RPG, UVa...). This technology is able to provide enough power up to THz for Schottky and I.5 THz for SIS mixers. New planars components are under development at JPL, U.Va, U.Michigan...).

HEMT oscillators, Quantum well oscillators are able to provide enough power up to 300-400 GHz; long Josephson junctions and flux-flow oscillators arrays are also opportunities to drive the SIS mixers up to 600-700GHz. CO2 lasers pumping submillimeter masers are used as LO sources in the range 300 GHz - 3 THz, but they need too high electrical power consumption for space applications: Heterodyned lasers diodes technology is under investigation!

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IV - SUBMILLIMETRE TECHNOLOGIES in the FIRST PROJECT

The Far InfraRed and Submillimetre Space Telescope (FIRST) is one of the four "Comerstone" projects in the ESA Long-Term Programme for Space Science, "Horizon 2000". This mission is devoted to high troughput spectroscopy and photometry in the submillimetre and far-infrared wavelength range. FIRST is foreseen to have a 3m diameter radiatively cooled Cassegrain telescope equiped with a payload consisting of a multichannel, very high spectral resolution heterodyne receiver (table 1) and an imaging medium and spectrometer and photometer, covering the 85-900 µm wavelength band (table 2). FIRST will open up this virtually unexplored part of the spectrum which cannot be observed from the ground, and is only partially accessible from airborne platforms.

With its high throughput, low thermal background, extensive wavelength coverage, and high spatial and spectral resolution, FIRST will offer superb sensitivity for both photometry and spectroscopy. Its multiband instruments will give unprecedented information on the physics, chemistry and dynamics of interstellar, circumstellar, planetary and cometary gas and dust, resulting in a quantum step forward in the study of the cold universe. It will be the first multipurpose submillimetre and far-infrared space observatory available to the world-wide astronomical community.

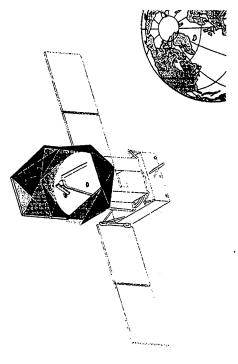


Figure 7: The FIRST spacecraft in orbit (artist view)

Receiver band # Mixer type	1 & 2 SIS	3 & 4 SIS	5 & 6 SIS	7 & 8 SIS	9 STS
v (GHz)	490 - 650	600 - 750	700 - 850	800 - 950	950-1200
Beam FWHM	48 - 36	39 - 31	34 - 28	29 - 25	25-20

Table 1: FIRST MultiFrequency Heterodyne (MFH) receiver frequency bands

Wavelength range 85-210 µm 85-210 µm 210-300 µm 85-210 µm 210-280 µm 280-600 µm 600-900 µm	85-210 µm	85-210 µm	210-300 µm	85-210 µm	210-280 µm	280-600 µm	mu 006-009
Filter bands	5	5	1	2	1	1	-
mode	hi-res.	med-res.	med-res.	photom.	photom.	photom.	photom.
Detector	photo- conductor	photo- conductor	short wavelength bolometer	photo- conductor	short wavelength bolometer	short + long wavelength bolometer	long wavelength bolometer

Table 2: Modes of operation

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v · CONCLUSION :

For most observations in the Earth's, planets and comets atmospheres, sensitivity is not nearly as critical an available from current room-temperature of passively cooled semiconductor-diode radiometers. For the most part, the emphasis for millimeter and submillimeter-wave, Earth remote sensing applications has been on pushing to higher frequencies (up to 3 THz), increasing the instantaneous bandwidth, improving device reliability and reducing radiometer issue as it is for stellar astrophysics. A large number of key molecular transitions can be observed with the sensitivity complexity and cost.

For astrophysic, very sensitive and very high spectral resolution heterodyne spectroscopy $(R_{max} \ge 10^6)$ are requiered. SIS mixers in the 500 to 1200 GHz range and flexible backend spectrometers with more than 4 GHz instantaneous bandwidth will be used on the FIRST project. Significant progress is being made on both mixer performances and junctions reliability as well as cryocooler technology (Sterling closed cycle cryogenerator and JT stage, submillimetric receivers will fly in space sometime in the very near future ... Pulsed Gaz Tube...). It seems no doubt that SIS heterodyne

Callech, Pasadena (CA, USA), for their subtential participations to this paper and CNES, ESA, NASA for funding the Acknowledgements: to the FIRST heterodyne payload team, with ESTEC-ESA, (the Netherlands), as well as JPLsubmillimeter developments.

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This paper has been made from the listed articles on the following references; using mainly the EOS-MLS and the FIRST ESA reports

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Millimetre Wave & Terahertz Waveguides & Measurements



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Department of Electronic & Electrical Engineering

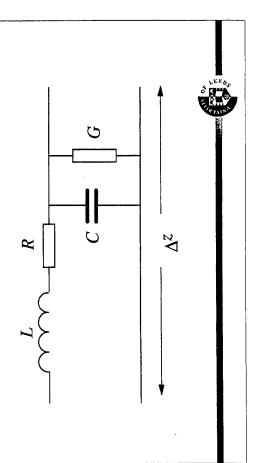
The University of Leeds Leeds LS2 9JT, U.K.

Agenda

- Some fundamentals and useful definitions
- The problems with increasing frequency
- Reflectometry
- six-ports and related technology
- quasi-optical techniques
- Network analysis
- down-converters for vector network analyzers
- wafer probing
- calibration issues
- Spectrum analysis



Review of Transmission Line Fundamentals



Transmission Line Fundamentals (2)

 ν and i are of the form $e^{j\omega t}$

$$v(z) = K_0 e^{-\gamma z} + K_1 e^{+\gamma z}$$

$$\gamma = \sqrt{(R + j\omega L)(G + j\omega C)}$$
 propagation constant

$$Z_0 = \sqrt{\frac{R + j\omega L}{G + j\omega C}}$$

characteristic impedance

if
$$R = G = 0$$
 (lossless), $Z_0 = \sqrt{\frac{L}{C}}$



Transmission Line Fundamentals (3)

$$\gamma = \alpha + j\beta
= \sqrt{j\omega\mu(\sigma + j\omega\varepsilon)}
\alpha = \omega_1 \sqrt{\frac{\mu\varepsilon}{2}} \left(\sqrt{1 + \frac{\sigma^2}{\omega^2 \varepsilon^2} - 1} \right)$$

$$\beta = \omega_1 \sqrt{\frac{\mu\varepsilon}{2}} \left(\sqrt{1 + \frac{\sigma^2}{\omega^2 \varepsilon^2} + 1} \right)$$
rad/m



Transmission Line Fundamentals (4)

■ Dielectric loss (tan d)

- modify with filling factor $\neq 1$

Radiation loss

 Conductor loss - skin effect

$$R_{dc} = rac{
ho \ell}{A}$$

$$R_s = \frac{1}{-c} = \sqrt{\frac{1}{2}}$$

$$R_s = \frac{1}{\sigma \delta} = \sqrt{\frac{1}{2}}$$

$$\dot{Z}_s = R_s + j\omega L_i$$

$$R_s = \frac{1}{\sigma \delta} = \sqrt{\frac{n g \mu}{\sigma}}$$
$$L_t = R_s / \omega$$

- semiconductors

Leakage loss

Transmission Line Fundamentals

- Useful Definitions

Voltage
$$V = E_i + E_r$$

Current $I = \frac{E_i + E_r}{Z_0}$

VSWR
$$\sigma = \frac{|E_i| + |E_i|}{|E_i| - |E_i|}$$

VSWING =
$$\frac{|E_i| - |E_r|}{|E_i| - |E_r|}$$

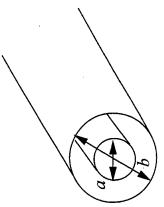
Reflection Coefficient $\Gamma = \frac{E_r}{E_i} = \frac{Z_L - Z_0}{Z_L + Z_0}$

 $(\rho Z \theta)$

$$\rho = \frac{\sigma - 1}{\sigma + 1} \qquad \frac{Z_L}{Z_0} = Z_L = \frac{1 + \Gamma}{1 - \Gamma}$$

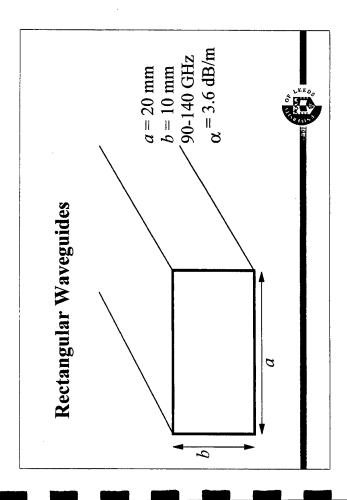


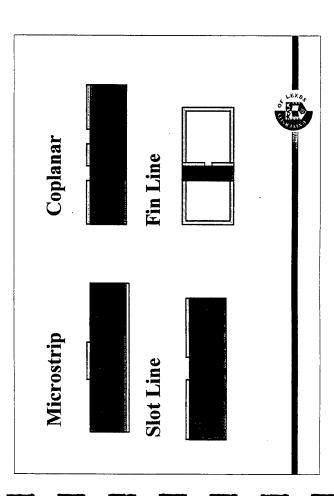
Coaxial Line



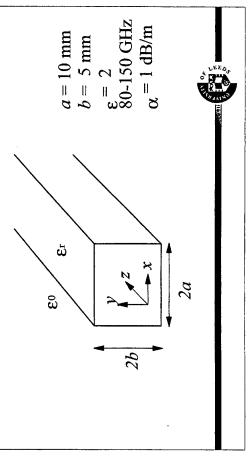








Rectangular Dielectric Waveguide



Some useful definitions

- Limits for operation of coaxial lines
- waveguide modes
 - loss
- tolerances and manufacturability

Loss at 1GHz (dB/m)	0.1	0.2	0.4	0.5	9.0	0.8	1.4	
f max (GHz)	8.5	18	34	40	20	65	110	
(mm)	6.08	3.04	1.52	1.22	1.04	0.80	0.43	
(mm)	14	7	3.5	2.82	2.4	1.85	1	



Some useful defintions (contd.)

■ Waveguide specifications

		_	_						_				
Attenuation (dB/m)*	0.35	9.0	2'0	6.0	1.3	1.7	2.3	3.3	4.6	6.5	8.5	11.6	at bigh frequency and of hand (annual Ag)
Cutoff (GHz)	14.047	21.081	26.342	31.357	39.863	48.350	59.010	73.840	90.840	115.750	137.520	173.280	ney and of han
Tolerance (μm)	+5.1	±3.81	+2.54	±2.54	±2.54	±2.54	±2.54	±1.27	±1.27	±1.27	±1.27	±1.27	at hinh fragress
ID (a x b) (mm)	10.668 x 4.318	7.112 x 3.556	5.690 x 2.845	4.775 x 2.388	3.759 x 1.880	3.099 x 1.549	2.540 x 1.270	2.032 x 1.016	1.651 x 0.8255	1.295 x 0.6477	1.092 x 0.5461	0.8636 x 0.4318	•
Waveguide EIA	WR-42	WR-28	WR-22	WR-19	WR-15	WR-12	WR-10	WR-8	WR-6	WR-5	WR-4	WR-3	
Frequency (GHz)	18-26.5	26.5-40	33-50	40-60	50-75	06-09	75-110	90-140	110-170	140-220	170-260	220-325	
Band	×	Ka	σ	ם	>	ш	м	4	۵	5	>	r	



Use of Waveguides at Terahertz Frequencies

- Losses increase rapidly with frequency
- Fabrication difficulties, tolerances
- problems of construction of components inside guide
- Surface resistance
- can be up to 25% worse than theory
- Surface roughness
- Power handling



Quasi-optical systems

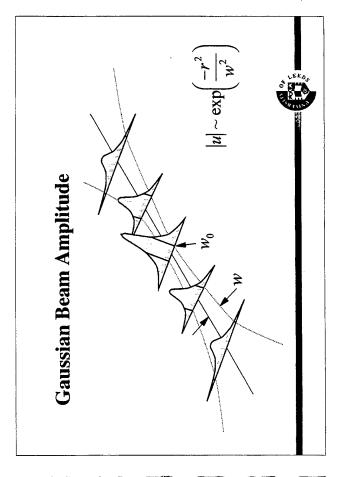
- Dielectric guides (fibres) work well for visible and near-visible - free-space very low loss and well-suited to millimetre applications.
- Ray optics, beams, lenses, etc. assume sizes which are thousands of wavelengths and transmitted via plane wave beams.
- Mode) small beam size, phase-front curvature, etc. ■ Can make compact using GBM (Gaussian Beam
- Fundamental mode has no cutoff frequency.

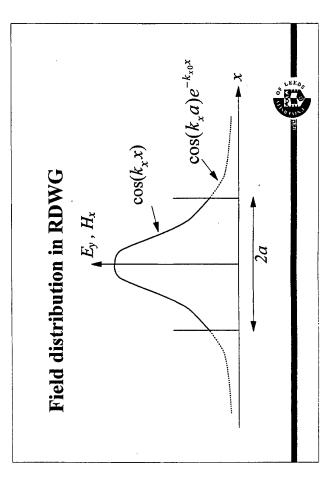


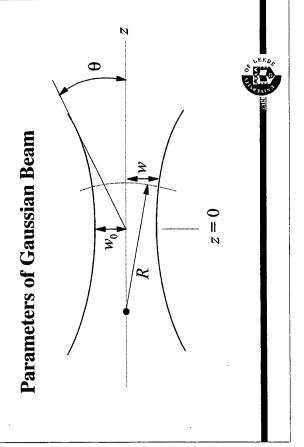
Gausssian Beams in Free Space

- \blacksquare Usual techniques of geometrical optics require components at least 100λ
- Issues of diffication, focussing collimation, etc.
 - Gaussian beams
- paraxial (cross-section small enough to be considered plane
- scalar field distribution
- minimum value at beam-waist (quasi-focus)
- e.g. for $\lambda = 1$ mm, feed aperture ratio 10 beam waist approx 6 mm approx. 120 mm between 40mm lenses/mirrors
 - power losses < 0.1 dB









Gaussian Beam Mode Theory (1)

$$\nabla^2 \psi + k^2 \psi = 0$$
 where $k = 2\pi/\lambda$ if we define

 $\psi = u(x, y, z) \exp(-jkz) \exp(j\omega t)$

and assume $\frac{\partial^2 u}{\partial z^2} \to 0$

 $\frac{\partial^2 u}{\partial x^2} + \frac{\partial^2 u}{\partial y^2} - 2jk \frac{\partial u}{\partial z} = 0.$

Gaussian Beam Mode Theory (2)

The fundamental mode solution is

$$u = \frac{w_0}{w} \exp\left(\frac{-r^2}{w^2}\right) \exp\left[-j(kz - \phi)\right] \exp\left(\frac{-jkr^2}{2R}\right)$$

where
$$w^{2} = w_{0}^{2} \left[1 + \left(\frac{\lambda z}{\pi w_{0}^{2}} \right)^{2} \right] \qquad R = z \left[1 + \left(\frac{\pi w_{0}^{2}}{\lambda z} \right)^{2} \right]$$

$$\phi = \arctan\left(\frac{\lambda z}{\pi w_{0}^{2}} \right) \qquad r^{2} = x^{2} + y^{2}$$

for large values of |z|, $\theta = \frac{\lambda}{\pi w_0}$



Scattering Parameters

$$b_1 \stackrel{\circ}{=} a_1$$
 2-port $a_2 \stackrel{\circ}{=} b_2$ network $a_2 \stackrel{\circ}{=} b_2$

$$b_{1} = S_{11}a_{1} + S_{12}a_{2}$$

$$b_{2} = S_{21}a_{1} + S_{22}a_{2}$$

$$\begin{pmatrix} b_{1} \\ b_{2} \end{pmatrix} = \begin{pmatrix} S_{11} & S_{12} \\ S_{21} & S_{22} \end{pmatrix} \begin{pmatrix} a_{1} \\ a_{2} \end{pmatrix}$$

 $S_{11} = \frac{b_1}{a_1} \bigg|_{a_2=0}$ input reflection coefficient with output matched

$$\begin{vmatrix} a_1|_{a_2=0} \\ -b_2 \end{vmatrix} = 6$$

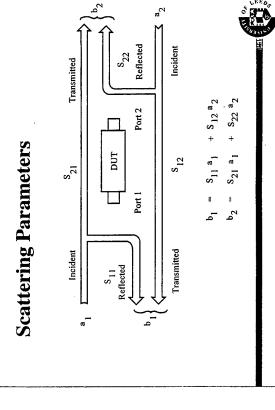
 $S_{21} = \frac{b_2}{a_1}$ forward transmission coefficient with output matched

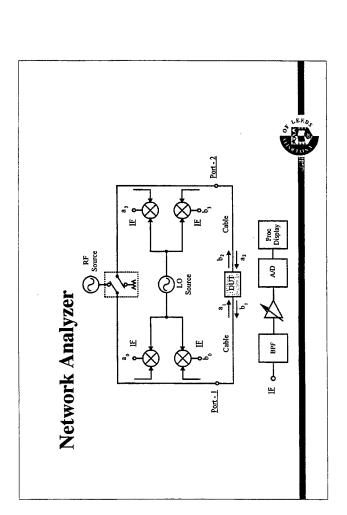


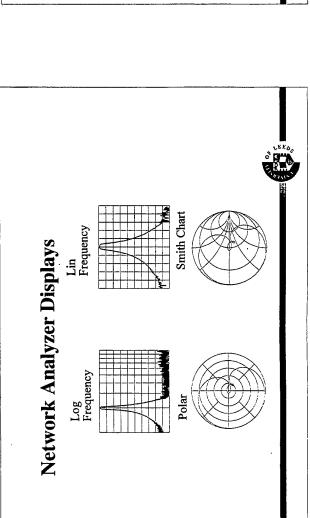
Basic measurement issues

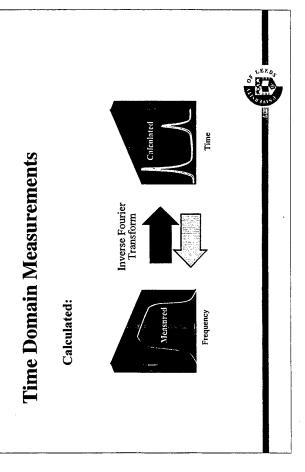
- Sources
- powerspurious
 - match
- Detectors
 - diodes
- bolometers
- Downconverters
- Passive elements
- connectors and flanges
- calibration components

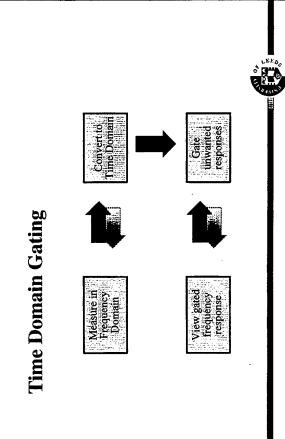










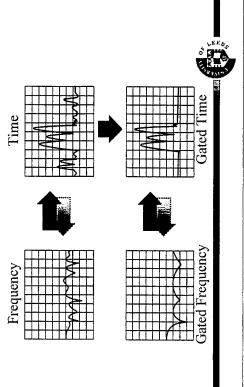


Time Domain Example Input/Output Launches

Six-port reflectometer

(P1)

(P0)



DUT

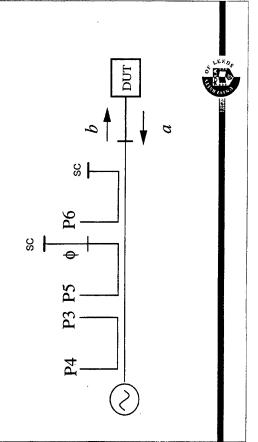
P2

Reflectometers

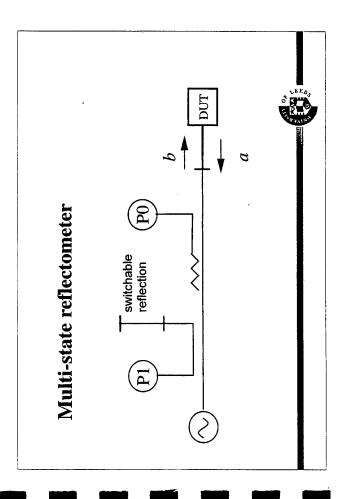
- Dual-directional couplers scalar detection
 - magnitude only
- low cost
- limited dynamic range
- Six-port and related techniques (vector)
- dynamic range depends on detectors
- lowest cost vector solution
- slow
- Quasi-optical techniques
- Vector network analyzer range extenders

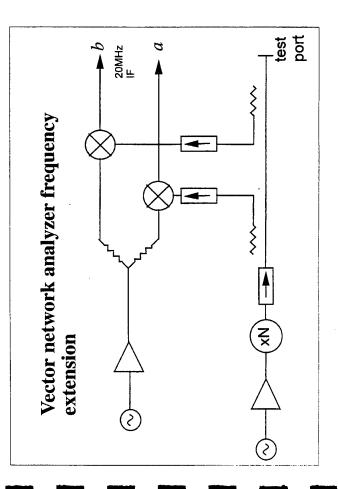


Six-port reflectometer







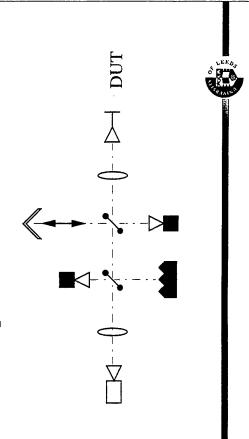


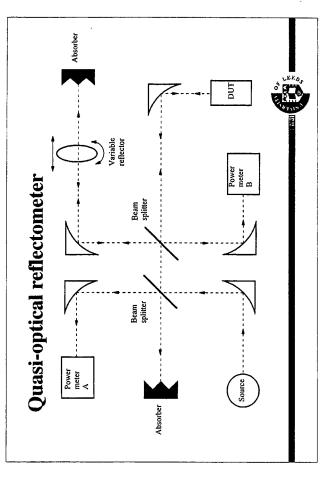
Vector network analyzer frequency extension

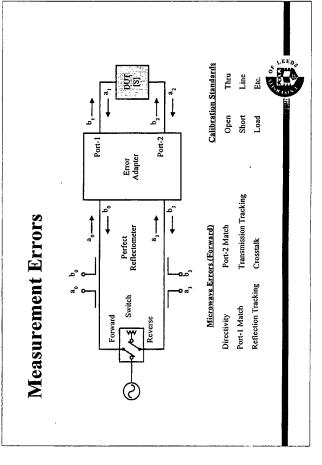
- Synthesizer + frequency multiplier as mm-wave source.
- Harmonic mixers allow use of 2-8 GHz L.O.
- phase lock or synthesis ensures that IF is precisely 20 MHz required for receiver.
- resolution and multiplication factor determine stimulus frequencies.
- Full two-port operation, error correction and time domain available.



Quasi-optical reflectometer





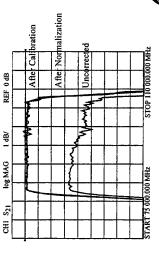


Accuracy Improvement

Cal Type	When to Use	Errors Removed
Uncorrected	* Transmission Measurement * Reflection Measurement	None
	Convenient but generally not accurate	
Response (Normalization)	Transmission Measurement Reflection Measurement When highest accuracy not required	Tracking only (Frequency response)
1. Port	* Reflection Méasurement Highest accuracy for 1-port dévrices	Directivity Port 1 March Reflection Tracking
Full 2-Port	Fransmission Measurement Reflection Measurement Highest accuracy for 2-port devices	Directivity Port-1 and Port-2 Match Reff & Trans Tracking Crosstalk

Accuracy Improvement

Calibration Removes Frequency & Response Mismatch Errors





Error Correction Methods

[2 čondtitons] S known Reflects (XXZ) on port-2 [3 conditions]	[1 condition] 3 known Reflects (XYZ) on port-1 or port-2 [3 conditions] 3 known Reflects (XYZ) on port-1 [3 conditions]	[4 conditions] Thru (T) or Line (L) with known S-parameters [4 conditions] Unknown Line (U) with S _D = S ₁ ; [1 condition]	TXYZ & LXYZ UXYZ
Known/Match (M) on port-1 and port-2 [2 conditions]	Unknown equal Reflect (R) on port-1 and port-2 [1 condition]	Thru (T) or Line (L) with known S-parameters [4 conditions]	TRM&LRM
Line (L) with known S ₁ , and S ₂₂ [2 conditions]	Unknown equal Reflect (R) on port-1 and port-2 [1 condition]	Thru (T) or Line (t.) with known S-parameters [4 conditions]	TRL & LRL
3 known Reflects (OSL) on port-2 [3 conditions]	3 known Reflects (OSL) on port-1 (3 conditions)	Thu (I) with known S-parameters [4 conditions]	TOSE

A Thru Measurement with Terminations on Port-1 and Port-2 is also Required for Leakage Calibration A Known Reference Impedance and a Port-1 to Port-2 Connection are Required



System equations (TOSL)

Actual and measured DUT

$$\begin{bmatrix} a_1 \\ a_2 \end{bmatrix} = \mathbf{S_A} \begin{bmatrix} b_1 \\ b_2 \end{bmatrix} \quad \begin{bmatrix} b_0 \\ b_3 \end{bmatrix} = \mathbf{S_M} \begin{bmatrix} a_0 \\ a_3 \end{bmatrix} \quad \mathbf{S_{A,m}} = \begin{bmatrix} S_{114,m} & S_{124,m} \\ S_{214,m} & S_{224,m} \end{bmatrix}$$

Error adaptor
$$\begin{bmatrix} b_0 \\ b_3 \\ a_0 \end{bmatrix} = \mathbf{T} \begin{bmatrix} a_1 \\ b_1 \\ b_2 \end{bmatrix} \qquad \mathbf{T} \equiv \begin{bmatrix} T_1 & T_2 \\ T_3 & T_4 \end{bmatrix} = \begin{bmatrix} t_{00} & t_{03} & t_{01} & t_{02} \\ t_{10} & t_{13} & t_{11} & t_{12} \\ t_{10} & t_{13} & t_{11} & t_{12} \end{bmatrix}$$



Measured S - Parameters

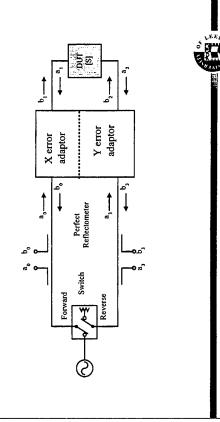
$$\mathbf{S}_{m} = (\mathbf{T}_{1}\mathbf{S}_{A} + \mathbf{T}_{2})(\mathbf{T}_{3}\mathbf{S}_{A} + \mathbf{T}_{4})^{-1}$$

Actual DUT S - Parameters

$$\mathbf{S}_{A} = \left(\mathbf{T}_{I} - \mathbf{S}_{m} \mathbf{T}_{3}\right)^{-1} \! \left(\mathbf{S}_{m} \mathbf{T}_{4} - \mathbf{T}_{2}\right)$$



Three 2-port ("TRL")Calibration



System equations (Three 2-ports, "TRL")



M = X.A.Y

measured DUT

 $\mathbf{M_1} = \mathbf{X.C_1.Y}$

measured 2 - port + cal. std 1

 $\mathbf{M}_2 = \mathbf{X}.\mathbf{C}_2.\mathbf{Y}$ $\mathbf{M}_3 = \mathbf{X}.\mathbf{C}_3.\mathbf{Y}$

measured 2 - port + cal. std 3

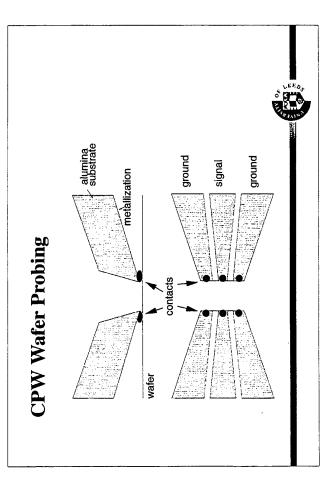
measured 2-port + cal. std 2

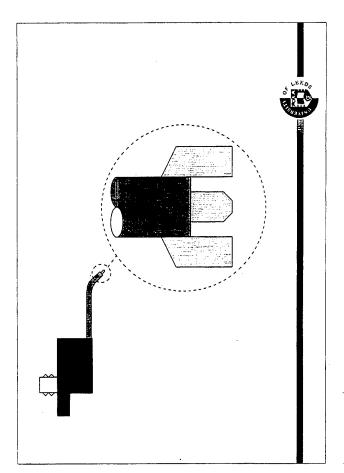


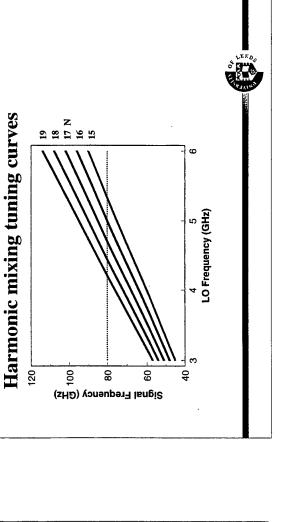
Calibration issues

- All the well-established cal. methods work at mm-wave.
- 1-port
- Short, offset short, (sliding or offset) load
- 2-port
- TRL (using precision waveguide shim)
 - On-wafer
- -SOLT
- LRL, LRM









Signal Identification

Harmonic mixing tuning curves

35

- Preselection
- usually impractical at mm-wave
- Image identification

Signal Frequency (GHz)

- change LO up and down by $2/n \times 1$ F.
- response at higher LO = n- mixing mode
 - response at lower LO = n+ mixing mode
- no response = incorrect value of n

LO Frequency (GHz)



Signal identification (contd.)

- Shift method
- reduce second LO by m MHz
- shift first LO by + or m/n MHz
- correct response at n- or n+ mixing mode when there is no frequency shift of displayed signal.
- Manual identification
- set span wide enough to see response pair
- responses separated by 2 x IF
- if closer together, then higher harmonic number if further apart, then lower harmonic number



Conclusions

- Conventional transmission lines and components are difficult to manufacture and have high loss.
 - Dielectric waveguide and quasi-optical techniques are recommended.
- Calibration and measurements successfully employ extensions of the same techniques developed at lower frequencies.



Recent developments in resonant tunneling components

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Overview of the lecture

- 1. Resonant tunneling transistors
 Definitions
 Growth and fabrication issues
 Characteristics
- 2. 3D integration of microwave sensors
 Passive components
 Active components
 Applications
- 3. Application of passive resonant tunneling components:
 A resonant tunneling pressure sensor

Resonant Tunneling Transistors (RTT)

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Performance is the basic driving force causing downscaling of devices in microelectronics. The minimal junction width is one of the fundamental downscaling limits for bipolar devices. This limit can be bypassed by replacing the junctions by tunneling barriers. The high tunneling speeds will move the frequency limitations.

However, also the minimally required width of the base layer (for reasons of resistivity) seems to be one of the fundamental limits. The preferred solution to overcome this limit is to use two-dimensional electron gasses as base layer because of their high mobility.

As soon as the first resonant tunneling devices were realized [1], one has tried to control the amount of tunneling carriers. In principle, every transistor in which resonant tunneling occurs could be called a resonant tunneling transistor, which then involves many devices [2]. In this workbook summary we consider a confined class of devices that can be studied as a group. We will only consider three terminal devices in which carriers tunnel resonantly from the emitter to the collector through a double (or multiple) barrier structure and in which a quantum well base layer is added in order to obtain control over the (electrical or optical) device output. Excluded from this overview are integrations of conventional transistors (HEMTs and MESFETS) and resonant tunneling devices. These will be addressed during the

1. An overview of four classes of RTI's.

We can classify all devices belonging to the area of resonant tunneling transistors in four groups according to their carrier nature and according to the position of the base quantum well. Considering the carrier nature, we can distinguish between unipolar and bipolar devices. A further classification is obtained by distinguishing between devices in which the quantum well, where confinement determines the tunneling current, forms the transistor base and others. In the latter case, an extra (modulation-doped) well is added to the structure. These four groups are summarized in table 1

	Unipolar devices	Bipolar devices
Base and tunneling quantum	Bound-State	Bipolar Quantum well
well are equal	Resonant Tunneling Transistor	Resonant Tunneling Transistor
Base and tunneling quantum	Resonant turneling	Resonant Tunneling
well are different	Hot Electron Transistor	Light Emitting Transistor

Table 1. The classification of RTT

1.1. Unipolar device.

The Bound-State Resonant Tunneling Transistor (BSRTT) has been proposed first by Schulman *et al.* [3] and Haddad *et al.* [4]. The principle of operation of this device is described in figure 1

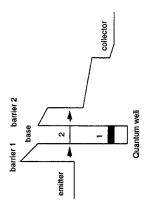


Figure 1 Principle of operation of the Bound-State Resonant Tunneling Transistor. The first energy level is strongly populated by confined electrons to obtain a good base conductivity. Changing the bias applied to this layer will change the band structure and in this way also the position of the second energy level. The second energy level is used for resonant tunneling from the emitter to the

The base quantum well is made of a semiconductor with a lower bandgap than the emitter layer so that the first energy level is far below the conduction band of the emitter. Tunneling can only occur using the second energy level.

The second barrier consists of 2 parts: the first part is a small but high barrier to have a high tunneling rate through the second energy level combined with a good confinement of that energy level at any bias. The second part is an additional barrier to prevent tunneling escape from the first energy level. This additional barrier needs to be effective even under a high base-collector bias. We will discuss this device more in detail during the lecture.

1.2. Unipolar device with separated base quantum well.

The Room-Temperature Resonant-tunneling Hot-Electron Transistor (RT-RHET) evolved from a transistor with a wide base and no confinement [5, 6] to a device with a 10 nm base and hence confinement [7]. Initially, the wide base was used to obtain a low base resistance (figure 2).

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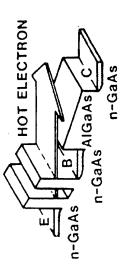


Figure 2 Principle of operation of the Resonant-tunneling Hot-Electron Transistor. The major part of the electrons that tunnel through the double barrier structure remains hot until they are above the base-collector separation barrier. The electrons that relax contribute to the base current. After reference [6]

60 nm to 10 nm [7]. In the case of a 10 nm wide base layer, this transistor corresponds to our definition of a Resonant Tunneling Transistor.

To obtain a good room temperature operation, the base width was reduced from

This device has been mentioned in 1991 by the Japanese Research and Development Association for future Electron Devices as the device that can realize a breakthrough in speed limitations [8].

A general band structure of a unipolar Resonant Tunneling Transistor with separated quantum wells is given in figure 3

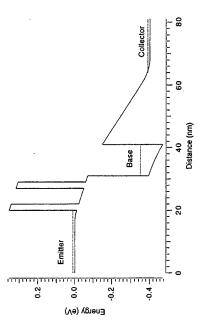


Figure 3 Band structure of the unipolar tunneling transistor with a separation between the tunneling quantum well and the base quantum well.

1.3. Bipolar Devices.

The bipolar device proposed by Seabaugh.

The bipolar alternative of the RTT has been proposed first by Ricco and

ч)

RESONANT TUNNELING TRANSISTORS

Solomon [9]. The first realization of this device, including the negative transconductance, has been reported by Seabaugh and Reed [10-12]. However, the operation of this device is still controversial [13].

It was realized using an n-type emitter and collector and a p-type double barrier tunneling structure, but also the inverse is conceptually feasible. A superlattice is added in both the emitter and the collector to restrict the tunneling in the quantum well to the second electron energy level. The base contact is realized by a p-implantation, providing the required isolation.

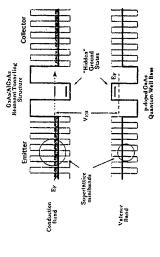


Figure 4 Schematic band diagram of the BiQuaRTT. After reference [11].

This device requires a high doping concentration in the base, which deteriorates the device characteristics. The multiple-quantum-well base equivalent of this structure has also been realized [14] and recently, clear negative differential resistance characteristics have been observed [15].

2. The bipolar device proposed by Iogansen.

Another bipolar device in which the base quantum well is used as the tunneling quantum well has been proposed recently by logansen [16]. A schematic band structure that also explains the principle of operation is given in figure 5. The electrons tunnel from the first electron state in the emitter quantum well to the collector using the second hole state in the base quantum well. The first hole state in the base quantum well is used to obtain a good base conductivity.

The difference with the devices in the previous section is twofold. It is an interband tunneling transistor and it is a triple-barrier device. It is bipolar because the emitter carriers are different from the base carriers. Nevertheless it also resembles strongly to the bound-state resonant tunneling transistor because the first energy level in the base is highly populated for a good base conduction combined with a second energy level used for tunneling. This means that almost all remarks that will be made further on enhanced base current due to intersubband relaxation in the Bound State Resonant Tunneling Transistor (BSRTT) also apply to this device.

Another major difference between the BiQuaRTT of Seabaugh and this device is that the base in this device can remain undoped. This will allow to obtain better characteristics.

RESONANT TUNNELING TRANSISTORS

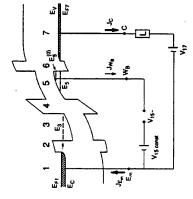


Figure 5 The interband resonant tunneling transistor by logansen. [16]

Other possible interband devices.

The triple barrier device proposed by Iogansen has both the advantages and GaSb/InAs_{0.91}Sb_{0.09} systems (see figure 6). In both cases we use AlSb as barrier material and for the p-type quantum well base layer we use the strained GaSb to confine the bound state. The asymmetry in the position of the additional bound state For the InAso,91Sbo.09 quantum well no strained quantum well is added because the disadvantages related to charging and alignment in triple barrier devices. In terms of advantages, it acts as a better energy filter and leads to sharper resonances. In terms of disadvantages, the large amount of charging screens the electric field across the quantum wells leading to large bistabilities in the I(V) characteristics. Another material system may be more advantageous for the interband resonant tunneling transistor. We propose the pseudomorphic InAs/GaSb_{0.91}As_{0.09} and band discontinuity in the conduction band is not big enough (see figure 1.1). The escape from the bound state is much lower in an interband device because interband tunneling occurs between two occupied states (with an opposite carrier), and the quantum well is introduced to diminish the tunneling escape from the quantum well although it can also have an important influence on the intersubband relaxation rate. emitter has a low occupation at high energies.

The major difference between this device and the Bound State Resonant Tunneling Transistor is that a higher base ground-level population can be easily obtained. No doping is required. A high position of the Fermi level in the base is almost automatically obtained using a lowly doped emitter. The Fermi level in the base can be easily varied without causing a leakage current to the emitter or collector layer. The leverage factor of the base steering will be high without deteriorating the device performance.

The quantum well base contact could be made in a similar way as the BiQuaRTT, i.e. by an implantation. However, for these devices, it is not that evident. InAs, a material with n-type background has to be made p-type by ion implantation. GaSb, a material with p-type background has to be made n-type by ion implantation. Little is known yet about these issues. It is preferable to make the base contact using the self-

aligned base contact technology discussed further in the text. The surface pinning of InAs prevents the free base layer from being depleted. No highly resistive part in the base resistance is present, which allows high frequency operation.

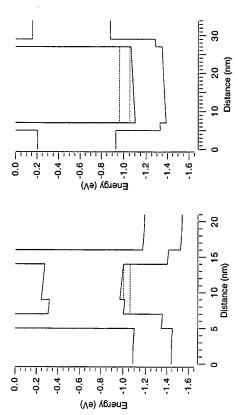


Figure 6 Suggestions for double-barrier interband resonant tunneling transistors in the InAs/GaSb_{0.91}As_{0.09} (left) and GaSb/InAs_{0.91}Sb_{0.09} (right) pseudomorphic systems.

The intersubband relaxation is as problematic in these devices as in all previously mentioned devices, but this is the only drawback of the proposed new device. However, type II heterostructures offer possibilities to prevent or reduce the optical phonon relaxation (which is the dominant relaxation) by a proper design of the inplane dispersion relations. The last part of this overview will address this concept.

1.4. Bipolar devices with separated quantum well's.

The Resonant Tunneling Light Emitting Transistors (RTLET's) and the Barrier Base Bipolar Resonant Tunneling Transistors (BBBRTT's) both belong to the class of bipolar Resonant Tunneling Transistors with separated tunneling and base quantum wells.

Resonant Tunneling Light Emitting Transistors (RTLET's).

Due to the reduced density of states, electrons in a 2DEG need to reside on a higher energy (Pauli principle) which makes a 2DEG unable to screen an electric field completely [17, 18]. The RTLET design is based on this incomplete screening. A relatively lowly-populated base quantum well acts as a transparent base which allows us to maintain the emitter-collector tunneling characteristics, including the NDR feature and oscillation region. At the same time, we can use the quantum-well base layer to inject minority carriers into the tunneling structure [19]. Two types are possible: the npn-type and the pnp-type. Both types are discussed below.

. npn-type RTLET

In the npn-type RTLET (see figure 7) electrons tunnel from the n-doped emitter to the n-doped collector through a double-barrier tunneling structure. The emitter-collector current-voltage characteristics are similar to the characteristics of an n-type double barrier tunneling structure, i.e. a region of oscillation or bistability. A quantum-well base layer is added behind the tunneling structure and is populated with holes (minority carriers).

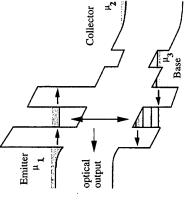


Figure 7 Schematic band diagram for the npn RTLET.

The base contact made on this quantum well layer allows the injection of minority carriers through the tunneling structure, without influencing the emitter-collector current-voltage characteristics. These injected carriers partly recombine in the tunneling quantum well which results in an optical output at the exciton wavelength. This optical output follows both independently the oscillation of the majority carriers and the applied changes in the injected base current. In this way an electro-optical heterodyne conversion could be obtained.

pnp-type

The operation of the pnp-type RTLET (see figure 8) is completely equivalent to the npn-type RTLET. The holes are the majority carriers and the electrons the injected minority carriers. The use of electrons as base carriers results in a higher base mobility and makes the technology to contact the base layer easier. However, the tunneling speed is lower for the holes (majority carriers) than for the electrons. This decreases the maximal operation frequency of this device.

This pnp-RTLET will be discussed during the lecture.

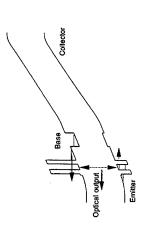


Figure 8 Schematic band diagram for the pnp RTLET.

Barrier Base Bipolar Resonant Tunneling Transistors (BBBRTT)

The possibility to grow materials with a staggered band alignment (see figure 1) allows the growth of a layer structure in which a quantum well in the valence band is a barrier in the conduction band (a) or vice versa (b). The base layers, populated with minority carriers can be in this case the barriers of the tunneling structure. The two possibilities that we suggest are shown schematically in figure 9. The classification above based on clearly separated quantum wells is, for this device not evident any more. Indeed, the wells are separated in energy and in space but the problem of e.g. carrier-carrier scattering during tunneling (resulting in a deterioration of the linewidth) is here also problematic and the spatial separation is not big enough to prevent indirect transitions.

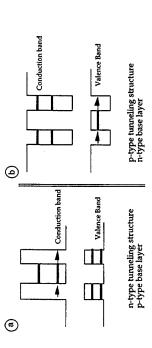


Figure 9 (a) Modulation of the resonant tunneling electron current due to hole quantum well base layers formed by the electron barriers and (b) the modulation of the resonant tunneling hole current due to electron quantum well base layers formed by the hole barriers.

Recently, Chow and Schulman have studied this layer structure (type a) as a diode [20] and observed huge intrinsic bistability due to large accumulation of holes

in the second barrier after bringing the barrier level above the Fermi level in the collector. We should be able to obtain these huge current changes by contacting the Al_xGa_{1-x}Sb barrier layer. A contact technology by etching and regrowing, similar to the RTLET, is almost impossible on this layer because the rapid oxidation of both the Al and the Sb. But a good base contact could be obtained by a p-type implantation.

The GaSb/AlSb (1 nm)/ GaSb (4nm)/AlSb (1 nm)/ GaSb structure, which is rather similar to the structure of type b, gave a poor peak-to-valley ratio at 77K [21]. On the devices of type (b) the same base-contact technology could be used as developed in this thesis for the RTLET.

2. The feasibility of the different options.

2.1. Theoretical comparison.

High intersubband relaxation.

In many Resonant Tunneling Transistors the second energy level in the quantum well is used for the tunneling from the emitter to the collector.

If this second energy level is separated from the first by more than the energy of an optical phonon (~36 meV), which is usually the case, intersubband relaxation will occur at a high rate [22, 23]. This will give rise to high emitter-base current and will reduce the amplification.

If the separation is smaller than the optical phonon energy, it becomes almost impossible to populate only the ground level via the contact layers. Moreover, the small energy separation does not allow the fabrication of an efficient additional barrier for the ground state. Also in this case we will have a high base current and a low amplification. The effects of intersubband relaxation will be discussed in more detail further in the text.

High carrier-carrier scattering rate during tunneling.

The linewidth of the energy level is strongly dependent on the scattering rate [24]. This broadening of the energy level deteriorates the tunneling characteristics. This is especially the case for devices that use the tunneling quantum well as the base of the transistor (devices described in sections 2.1 and 2.3).

· High carrier-dopant scattering rate during tunneling.

The devices that use the tunneling quantum well as the base usually require a high doping in order to obtain a good base conductivity. This doping deteriorates the linewidth and the tunneling characteristics in a similar way as described above.

Low leverage factor of the base steering.

All devices that have a quantum well base layer suffer from the fact that the leverage factor of the base steering is not unity. (see below). In contrast

with the two former topics, this handicap becomes more important when the charge in the base layer is smaller. This handicap applies to all four device types.

High recombination rate in the tunneling quantum well.

The presence of both electrons and holes will give rise to a large optical recombination rate, in all bipolar devices (devices described in sections 2.3 & 2.4). In the RTLET this is wanted because the optical output is the aim. In the BiQuaRTT, this recombination rate will give an increase in base current.

2.2. Technological comparison.

Base-to-collector separation is difficult.

In unipolar devices (devices described in sections 2.1 & 2.2) it is always difficult to foresee a good tunneling probability from the emitter via the base to the collector and to restrict in the same time the tunneling from the base to the collector for a much larger amount of carriers with a lower energy. In the bipolar devices, one can use the pn junction to separate the base from the collector.

The realization of a good Ohmic contact on a 10 nm thick layer is not evident.

In a traditional Ohmic metalization scheme, there is always a Schottky barrier present which is made very small by high semiconductor doping, penetrating in the semiconductor from the metal during the alloy process. This penetration is always a few nanometers, having spikes up to 80 nm. In the case of a contact on a quantum well, this is not allowable. This problem can be solved in several ways, using the PdGe technology, in which experiments indicate that no spiking occurs [25], using MBE-regrowth on the base contact or using an implantation in the case of a bipolar device.

Surface pinning completely depletes the free base layer.

A free base layer may result in a complete depletion of the base depending on the Fermi-level pinning. A remaining barrier of about 5 nm on top of the base quantum well is enough to stop the surface recombination rate and the remaining charge will be dependent on the band structure as determined by the pinning position [26].

The wet etching down to the base layer (10 nm) must be done under strict control

This problem does not occur for the bipolar devices where the contact is made by implantation.

Conclusions.

Resonant Tunneling Transistors have been proposed to overcome the scaling limits and speed restrictions of bipolar transistors. The limit of the minimal junction width can be overruled when junctions are replaced by tunneling barriers. The shorter devices allow to obtain a higher speed when the speed is restricted by the transit time through the device.

This overview summarized Resonant Tunneling Transistors with a two-dimensional electron gas as the base layer. Two major intrinsic problems have been reported to deteriorate the device performance, namely the low leverage factor of the base steering and the relaxation problems in the base layer.

the base steering and the relaxation problems in the base layer.

The low leverage factor of the base steering is a repercussion of the Pauli principle: additional electrons in the base layer are forced to reside on higher energies. As a consequence, the changes in the Fermi-level do result in much smaller changes in band structure and the base contact does not obtain a good control over the tunneling current.

The influence of intersubband relaxation in a resonant tunneling transistor on the performance degradation is similar to the influence of the recombination in the base layer of a bipolar transistor. Both effects result in a additional base current and a reduction of the gain. However, the intersubband relaxation rate is some orders of magnitude larger than the recombination rate in the base layer of a bipolar transistor. The reduction of this intersubband relaxation is a major topic.

The technological problems to realize a good Ohmic contact on this two-dimensional base layer are also compared in the different devices.

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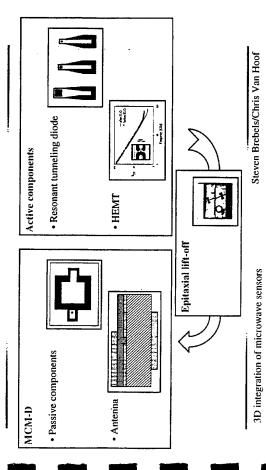
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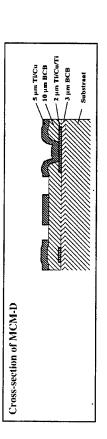
2. 3D integration of microwave sensors

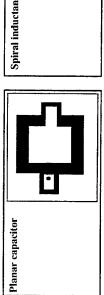
The following slides give an overview of our work on 3D integration of microwave sensors. Passive and active components have been realized.

3D integration of microwave sensors



Passive components in MCM-D



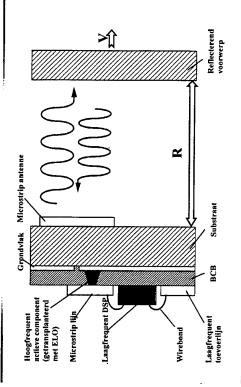


Spiral inductance

3D integration of microwave sensors

Steven Brebels/Chris Van Hoof

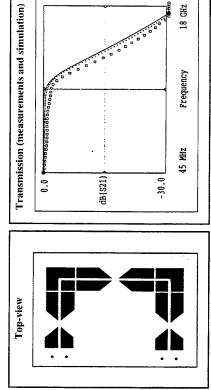
3D-integration of microwave sensors Aim



3D integration of microwave sensors

Steven Brebels/Chris Van Hoof

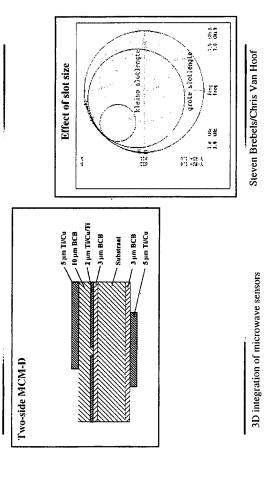
Example: Butterworth low-pass filter in MCM-D



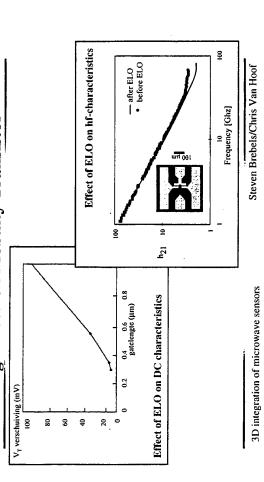
3D integration of microwave sensors

Steven Brebels/Chris Van Hoof

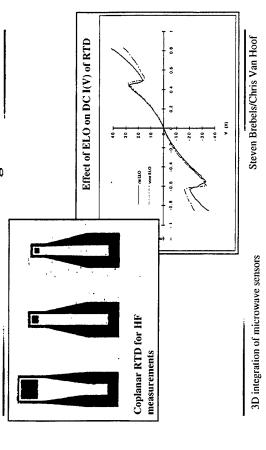
Realisation of integrated antenna in MCM-D



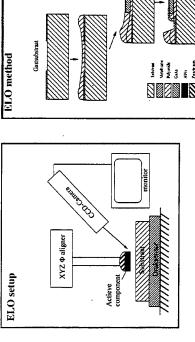
High Electron Mobility Transistor Active component:

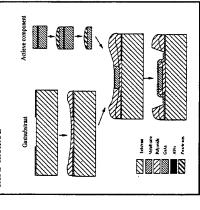


Resonant Tunneling Diode Active component:



Setup and Method Epitaxial Lift-Off



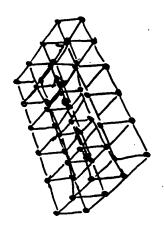


3D integration of microwave sensors

Steven Brebels/Chris Van Hoof

HOT ELECTRON MIXERS AND SIS-DETECTORS

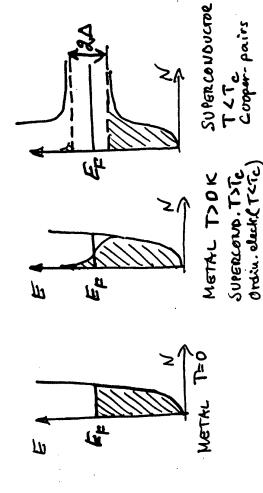
BY
ERIK KOLLBERG
Chalmers University of Technology
Göteborg, SWEDEN



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- The other electron is attracted by this positiv excess change.

Cooper pairs are created - Bosons

The energy draps for the two electrons:
a bandgop is created:



SIS: Superconductor-Insulator-Supercond. I = I = [0,(E) D_{(E+ev)} f(E) (4-f,(E+ev) - (4-f,(E)) f_{(E+ev)} dE SUPERCONDUCTOR NORMAL METAL 30 ů

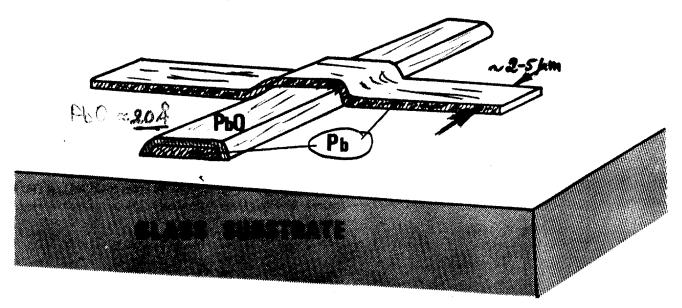
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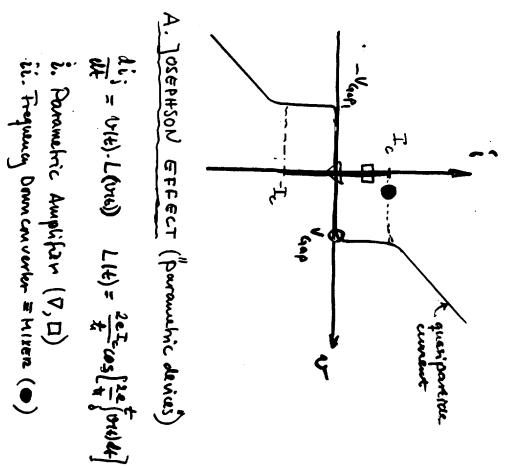
Planar Device on a substrate.



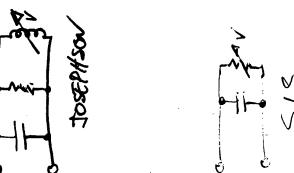
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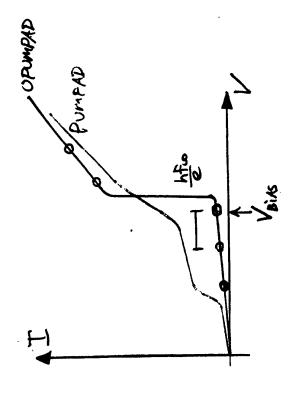
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B. Quasiparticle mixer ("texistive mixer")

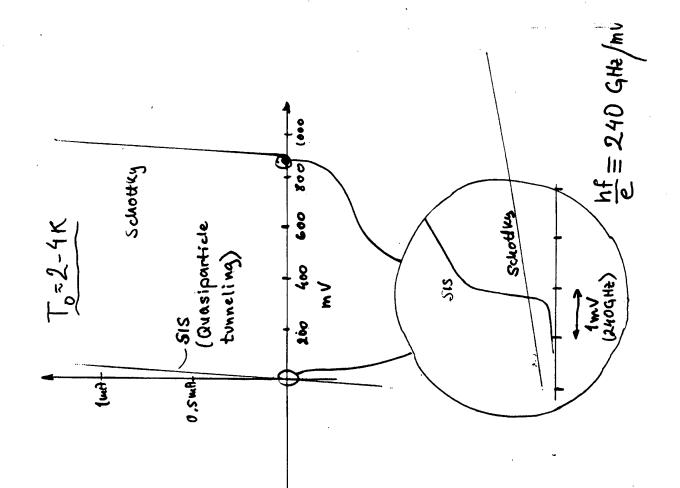








In = 2 Jr[e/6] In [1/6 + nht]



Why Low noise for SIS-mixer?

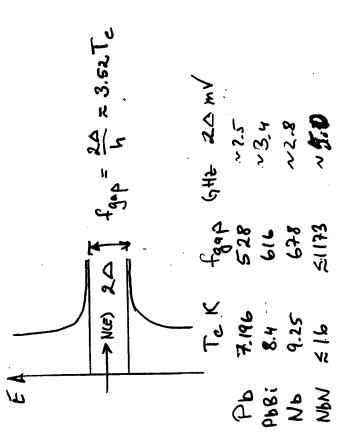
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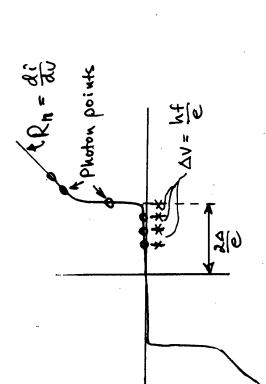
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- * Tew ~ 40 gk (cored)
- * excess note from Series relistance

Noise of an Sis element:

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- No suis resistance.





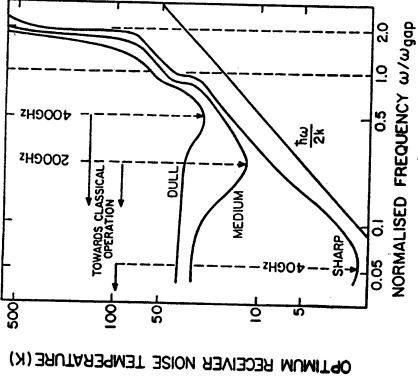
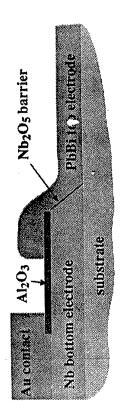


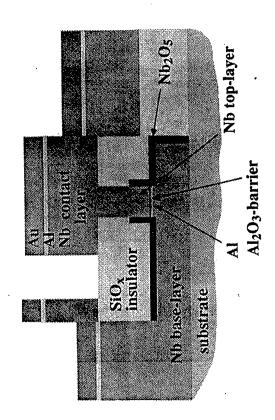
Figure 11. Predicted receiver noise temperature as a function of frequency for three synthetic I-y curves representative of a dull, medium and sharp SIS nonlinearity, after Feldman [21].

mixing [21]. Figure 11 summarizes part of the data obtained for the three I-V curves differing only in their sharpness of the current rise at the gap voltage. At each optimized, A double sideband mixer was assumed (i.e. LO and image conductance were were set equal to the signal conductance, this is often the for a small IF) and all by the millimetre-wave circuit). The load conductance was assumed to be tuned out which is close to the optimum value, and a gap voltage of 3mV and an IF noise temperature of 10K were chosen as typical values. From the data given in Figure 11,

Fabrication of SIS devices



Nb/Nb₂O₅/PbBi edge junction



Nb/Al-Al₂O₃/Nb trilayer junctions

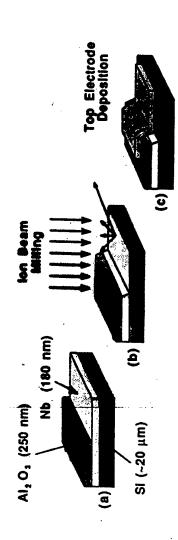
DSB receiver noise temperature 330-350 GHz = 100 K



Niobium edge junctions

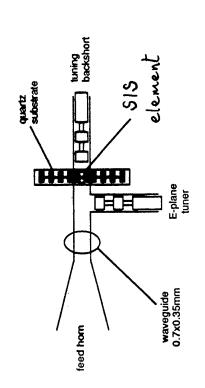
$$A = 0.2 \mu m^2$$
 $C = 30 \text{ fF}$
 $\omega RC = 3.3 @ 700 \text{ GHz}$

Nb - Nb0x - PbBi



mixer matching thing tuning tuning tuning tuning tuning

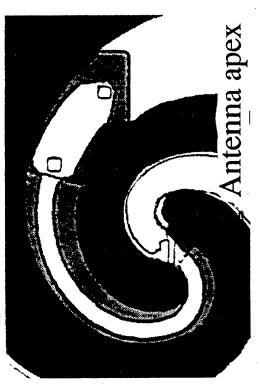
diagonal feedhorn





500 GHz SIS mixer Twin junction tuning circuit

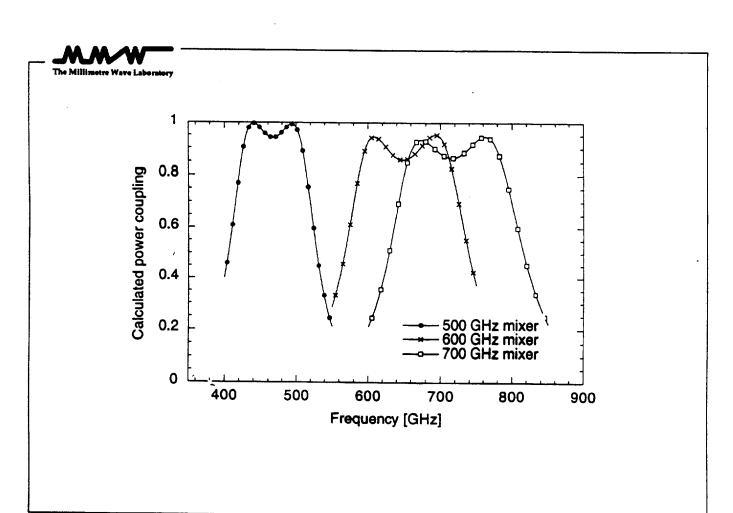




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Principle of twin junction tuning circuit



 $Y_1 = A + jB$ $Y_2 = A + jB$

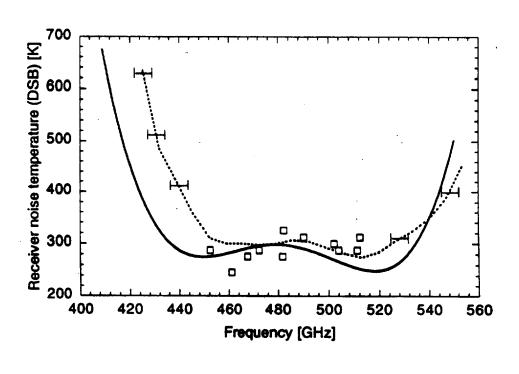
antenn

=(A-jB)+(A+jB)=2A

transformed to match

 $\rightarrow Y$ antenna





V.Yu.B. 95-03-15

Chalmers University of Technology Gothenburg, Sweden

Direction of main beam

Cr/Au antenna structure on SiO₂/Si₃N₄ dielectric membrane thickness 1.7 µm Antenna length L=6.7 λ_0 Opening width = $1.1 \lambda_0$ Total width = $2.85 \lambda_0$

Detector: room-temperature micro Bi bolometer thickness ≈ 100 nm $w \times 1 = 5 \times 10 \mu m$

resistance $\approx 100 \Omega$

BLTSA on thin dielectric membrane

- Detector

BLTSA Antenna

Membrane

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Principle of twin junction tuning circuit

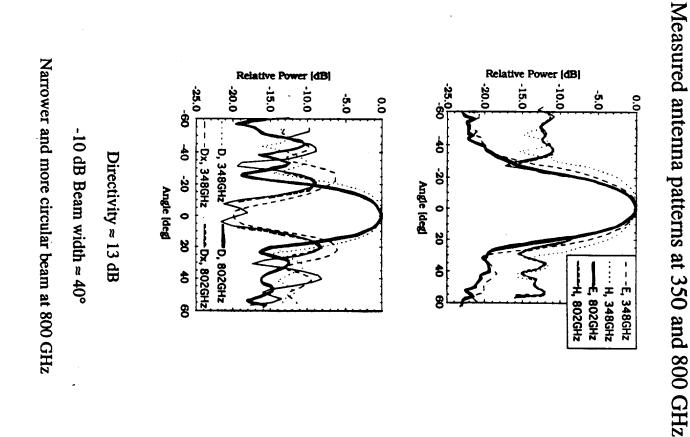
 $Y_1^* = A - jB$

=(A-jB)+(A+jB)=2A

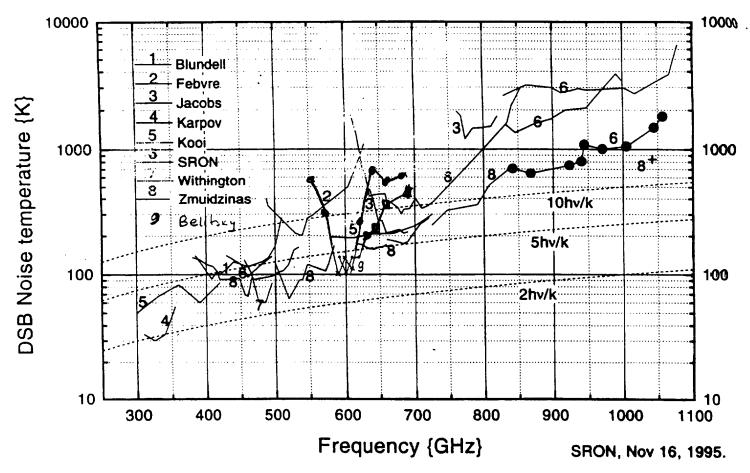
transformed to match

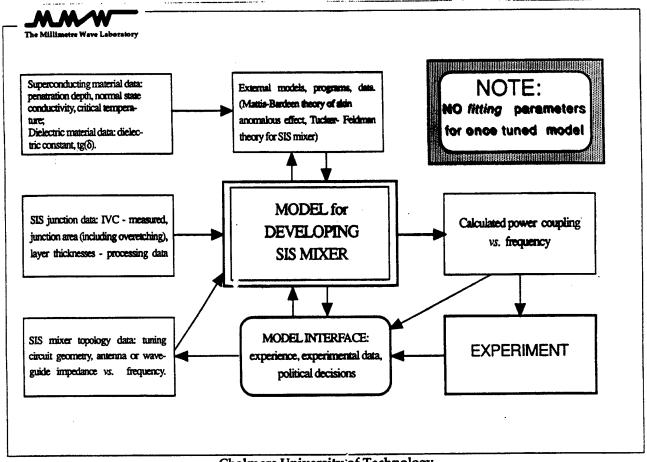
 $\rightarrow Y_{antenna}$

 $Y_1 = A + jB$



Sensitivity of SIS Heterodyne Receivers above 300 GH2





Victor Belitsky 95-08-31

Chalmers University of Technology Gothenburg, Sweden

HOT ELECTRON MIXERS

OLD HISTORY

Very low noise <u>InSb-mixers</u> have been used up to near 1 THz successfully

Bolometric type of detector element;

allows for maximum 1-2 MHz intermediate frequency only.

The hot electron bolometer mixer

Why?

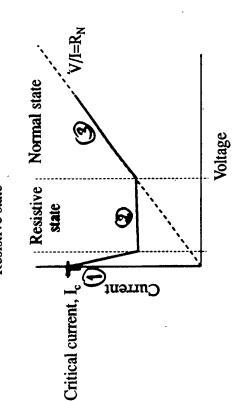
Frequency independent in the submillimeter range High conversion efficiency

Low noise determined by temperature fluctuations

Easy integration with antennas etc

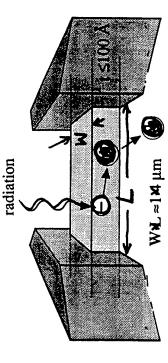
but

Relatively narrow IF bandwidth



The three states of the bolometer

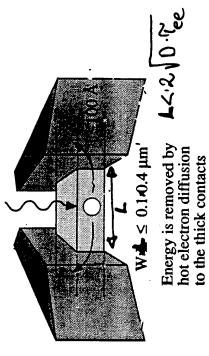
"PHONON-COOLED"



energy relaxation time .> $f_{IF} \approx 100\text{-}2000 \text{ MHz}$ Energy from hot electrons to Nb lattice to substrate lattice

" DIFFUSION-COOLED"

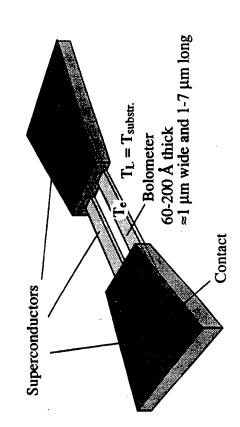
radiation



energy relaxation time -> $f_{\rm IF} \approx 2-3~{\rm GHz}$

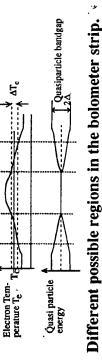
Thermal response time = Thermal Conductonce Thornal Capacitonce

- RESISTANCE of a Hot Electron Device changes with <u>electron</u> temperature T_e, lattice temperature T_L is constant.
- T_e depends on the total absorbed power





(b) Resistive transition region with "gradient in electron temperature" $T_c - \Delta T J 2 \Delta T_c - T_c + \Delta T_0 J 2$ Superconductor with $T_c - \Delta T_0 J 2$ $\frac{1}{L_{acs}}$ NORMAL REGION $T_c - \Delta T_0 J 2$



,

COMPARE I-V:

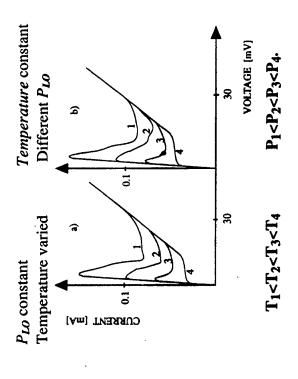
TK

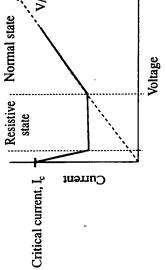
Superconducting T

Resistive state

Normal state

R Ω R_N

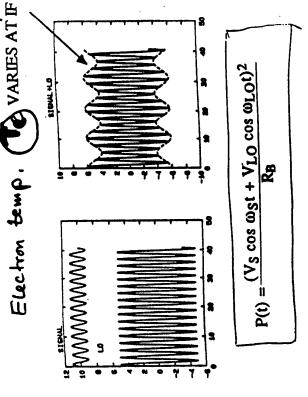




The three states of the bolometer

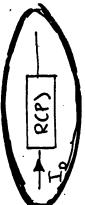
THz radiation Electron Bolometer Substrate, temperature C

HOT ELECTRON DEVICES ARE "ENVELOPE DETECTORS"

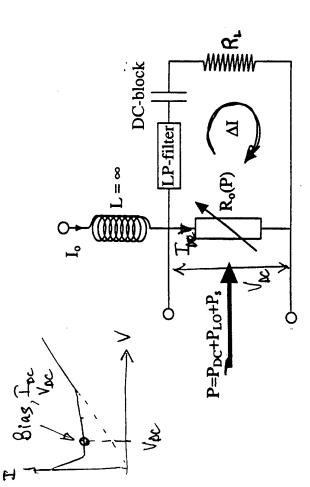


DEVICE RESPONSE

TIME ~ & (ENERGY RELAXATION TIME) — THUS DEVICE CURRENT DOES NOT FOLLOW DC I-V-CURVE — DEVICE RESISTANCE FOLLOWS THE ENVELOPE OF THE INSTANTANEOUS POWER



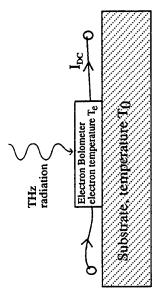
EQUIVALENT CIRCUIT OF HOT ELECTRON MIXER



LP-filter:

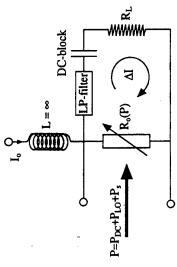
- The electron response time is long compared to inverse signal frequency.
 - Thus mixer performance is independent of signal frequency.

Insb: Arams 1966



Schematic drawing of a hot-electron bolometer device.

$$P_{RF}(t) = \frac{1}{2R_{BO}} \left(^{(V_{LO} \sin(\omega_{LO}t) + V_{S} \sin(\omega_{S}t))^{2}} \right)$$



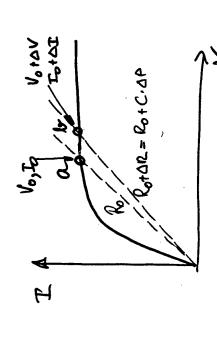
Equivalent circuit of bolometer with load.

Arams, 1966:

$$G = \frac{P_{IF}}{P_s} = 2C_o^2 \frac{P_{LO} P_{DC}}{(R_L + R_o)^2} \frac{R_L}{R_o} \left(I - C_o \frac{P_{DC}}{R_o} \frac{R_L - R_o}{R_L + R_o} \right)^{-2}$$

$$C_o = \frac{dR_o}{I_S}$$

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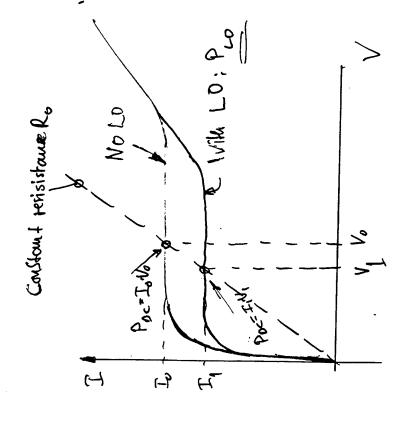


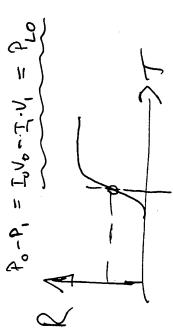
$$\Delta R = \frac{V_o + \Delta V}{I_o + \Delta I} - \frac{V_o}{I_o} \approx \frac{V_o}{I_o} \frac{\Delta I}{I_o} \left(\frac{\Delta V}{\Delta I} \frac{I_o}{V_o} - 1 \right)$$

$$\Delta P = (V_o + \Delta V)(I_o + \Delta I) - V_o I_o \approx V_0 \Delta I \left(\frac{\Delta V}{\Delta I} \frac{I_o}{V_o} + 1\right)$$

$$C_o = \frac{dR}{dP} = \frac{1}{I_o^2} \frac{AV}{AV} \frac{I_o}{I_o} - 1 = \frac{R_o}{P_{DC}} \frac{\left(\frac{dV}{dI}\right)_{DC} - R_o}{\left(\frac{dV}{dI}\right)_{DC} + R_o}$$

$$G = \frac{1}{2} \frac{P_{LO}}{P_{DC}} \frac{R_L}{R_o} \left(1 - \frac{R_o}{(dV/dI)_{DC}} \right)^2 \left(1 + \frac{R_L}{(dV/dI)_{DC}} \right)^{-2}$$

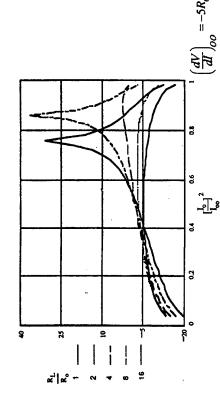




POSITIVE CONVERSION GAIN

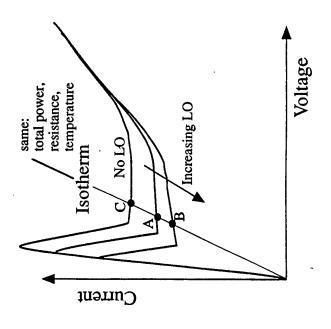
With $\left(\frac{dV}{dI}\right)_{oo}$ < 0 for the unpumped IV-curve and for certain values of $\frac{R_L}{R_o}$

Loss less than 6 dB or even Positive conversion gain.



WITH $\zeta_{=} 2C'^{2} \left(\frac{I_{oo}^{2}}{I_{oo}^{2}} \right)^{1 - \frac{I_{o}^{2}}{I_{oo}^{2}}} R_{o}^{L} \frac{1}{(R_{L}/R_{o} + 1)^{2}} \frac{1}{\left(1 - C' \frac{I_{o}^{2}}{I_{oo}^{2}} \frac{R_{L}/R_{o} - 1}{R_{O} + 1} \right)^{2}}$

RF COUPLING



$$\chi = \frac{P_{DC,A} - P_{DC,L}}{P_{LO,B} - P_{LO,L}}$$

 $P_{LO,B} - P_{LO,A} = \text{Difference in applied LO-}$ power between curve A and B

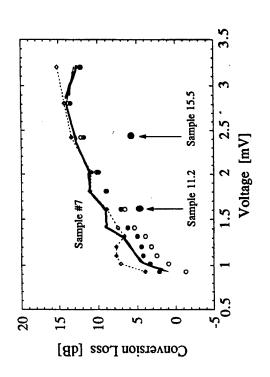
70/0/2 011

CONVERSION VS BIAS

2

50

Gain [dB]



Conversion Gain vs. $P_{DC}/(P_{DC} + P_{LO})$ for different IF load resistances. $R_L < R_O$. The differential resistance for the unpumped curve: dV/dI=∞, or C₀·I₀₀²=1

ŝ

0.0625 -0.125 25

MEASURED LOSS:

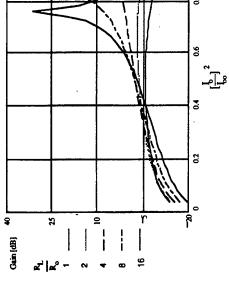
Solid line

CALCULATED LOSS:

From pumped curve:

Loss with calculated slope Loss with measured slope From unpumped curve:

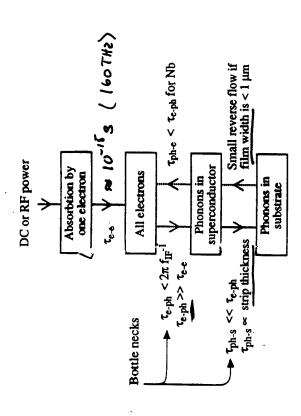
Circles
Diamonds Oots



Conversion Gain vs. $P_{DC}/(P_{DC}+P_{LO})$ for different IF load resistances. $R_L>R_0$. The differential resistance for the unpumped curve is negative: $dV/dI=-5\cdot R_0$, or $C_0\cdot I_{00}^2=1.5$.

2

CONDI TI ONS FOR HOT-ELECTRON MIXING



 τ_{e-ph} is material dependent and limits the IF bandwidth.

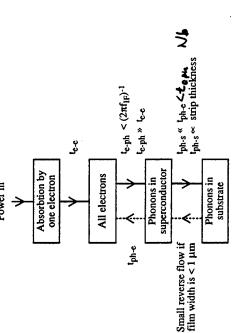
$$f_{\rm IF} < (2\pi t_{\rm e-ph})^{-1}$$
.

 $\tau_{\rm ph-s}$ is determined by the bolometer thickness. **t** < 100 Å

t_{s-ph} is determined by the bolometer-substrate contact area.

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RELAXATION PROPERTIES



			1		_	
	Expen-	mental	~ 0. (642	~ 54 Hz	2	
してからしょ	IF	[GHz]	0.3	20	100	
-	te-ph	[s]	3x10-10	10-11	10-12	
	te-e	[s]	10-11	<10-11	ė	
	Mate-	rial	Np.	NPN	HLSC	

CONVERSION GAIN AND IF IMPEDANCE VS INTERMEDIATE FREQUENCY

$C_o = dR/dP = [dR/dT] \cdot [dT/dP]$

Assuming

 $dT/dP \sim I/(I+j\omega \tau_e)$ and dR/dT = constant

$$C_o(\omega) = \frac{C_o(\omega = 0)}{1 + j\omega \tau_e}$$

Hence:

$$G = G(\omega = 0) \cdot \frac{1}{1 + (\omega \tau_{MIX})^2}$$

where

$$\tau_{MIX} = \frac{\iota_e}{1 - C_o I_o^2 \cdot \frac{R_L - R_o}{R_L + R_o}}$$

and

$$Z(\omega) = R_o \left(1 + \frac{2C_o I_o^2}{1 - C_o I_o^2} + \frac{1}{1 + i\omega t_{imn}} \right)$$

where

$$\tau_{imp} = \frac{\iota_e}{1 - C_o I_o^2}$$

IF BANDWIDTH

Onversion Constant

1.1 mV

1.4 mV

1.4 mV

1.4 mV

1.5 3.2 mV

1.6 ns

2.6 ns

2.6 ns

3.2 mV

1.8 ns

1.8 ns

Frequency [MHz]

Bandwidth around 100 MHz increases slightly for larger bias

with
$$\tau_{mix} = \frac{\tau_e}{1 + C_d I_d^2 \frac{R_o - R_L}{R_o + R_r}}$$
 from IV curve, $R_o = \frac{\sqrt{e}}{I_o}$

 τ_{mix} is 2.6, 2.14 and 1.83 ns respectively

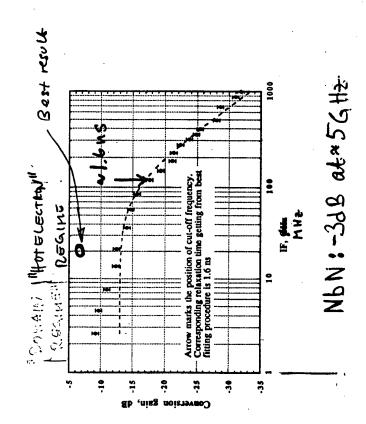
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13

12

NS

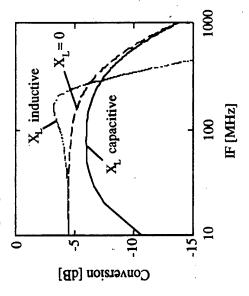
CONVERSION VS IF



Using a complex load impedance viz. $R_L - Z_L = R_L + jX_L$ we obtain for the frequency dependence of the conversion gain.

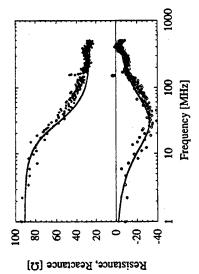
$$G = \frac{2\left(1 - \frac{I_o^2}{I_o^2}\right) \frac{\left(C_o I_o^2\right)^2}{\left(1 - C_o I_o^2\right)^2} R_o \cdot R_L}{\left[R_L + \left(\frac{dV}{dI}\right)_{pumped} - \omega \tau_e \cdot \frac{X_L}{1 - C_o I_o^2} + j \left[X_L + \omega \tau_e \cdot \frac{R_o + R_L}{1 - C_o I_o^2}\right]\right]^2}$$

Hence it should be possible to improve the bandwidth somewhat by a proper design of the load circuit $Z_{\rm L}$.



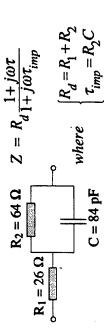
IF Bandwidth for different load reactances.

IMPEDANCE



Dots Lines

measured IF impedance impedance of load



Impedance time constant,

Measured From IV-curve

 $\tau_{imp} = \text{R2C} = 5.4 \text{ ns.}$ $\tau_{imp} = \frac{\tau_e}{1 - C_o l_o^2} = 5.1 \text{ ns.}$

Te from mixer exporruent

HE 5/9/94

THEORETICAL

Assuming:

Temperature fluctuations $\Delta \theta \Rightarrow$

 \Rightarrow Resistance fluctuations $\Delta R \Rightarrow$

 \Rightarrow IF voltage fluctuations $\Delta V \approx I_{DC} \times \Delta R$

≡ IIF-NOISE OUT FROM MXR

TIF, noise, out= $G \times T_{Mixer,FL}$

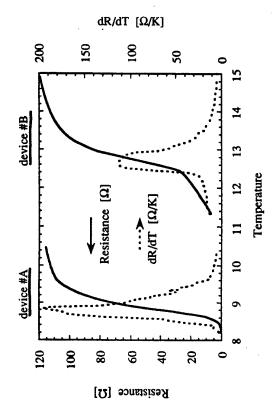
TMixer= $T_{noise,out}/G = T_{MFL}$

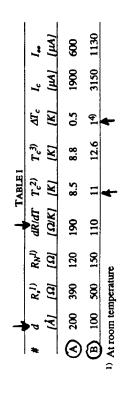
is the electron temperature

 C_e is the electron heat capacity

 τ_{e-ph} is the electron-phonon relaxation time

 P_{LO} is the absorbed LO power.

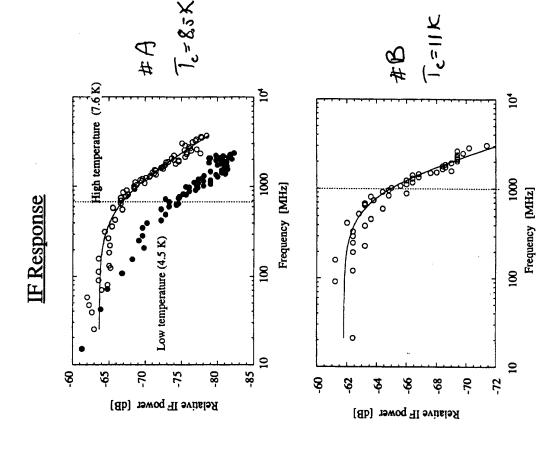




2) At onset of resistance

3) At maximum dR/dT

4) Excluding the foot structure below T_c.



Bandwidth⁻¹ =
$$2\pi \tau_{mix} \propto \tau_{e-ph} \propto \theta^{-1.6} \approx T_c^{-1.6}$$

$$680 \left(\frac{11}{8.5}\right)^{1.6} = 1020 \ MHz$$

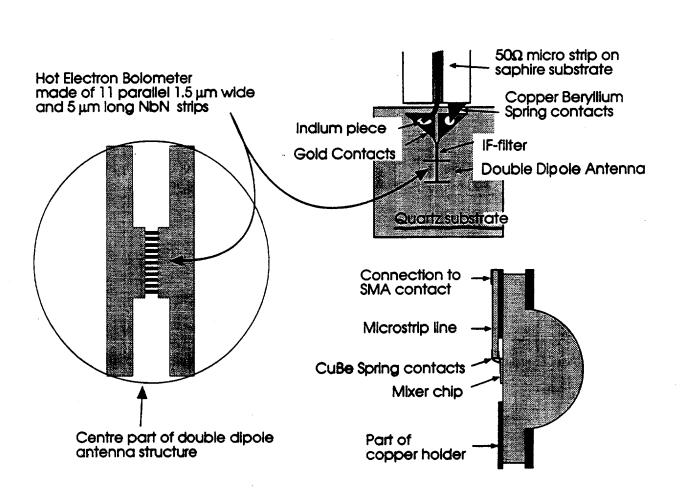


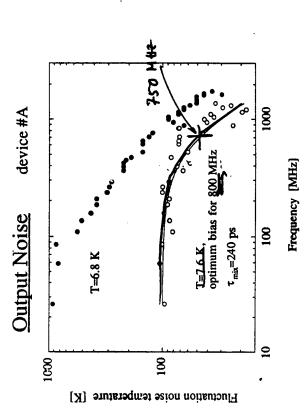
ARTICLES AND A STREET

11 parallel 1.5 µm wide and 5 µm long NbN strips

Hot Electron Bolometer

film thickness 100-200 Å





TFL has the same roll-off frequency as the IF response

IMPROVEMENTS

Improved performance expected if:

- 1. smaller ΔT_c , larger dR/dT -> larger C and gain
- higher signal frequency -> more uniform absorption along strip-> larger C and gain
- 3. Better film quality expected for films on sapphire or silicon.

4. Thinner superconductor

WEDNESDAY JULY 3

Deutsche Forschungsanstalt für Luft- und Raumfahrt e.V.

Schottky Barrier Devices for THz Applications

Prof. Dr. H.-P. Röser DLR, Institute for Space Sensor Technology Rudower Chaussee 5 12489 Berlin Germany NATO ASI New Directions in Terahertz Technology



German Aerospace Research Establishment Institute of Space Sensor Technology

HIGH RESOLUTION HETERODYNE SPECTROSCOPY

Range: 600 GHz - > 3,000 GHz

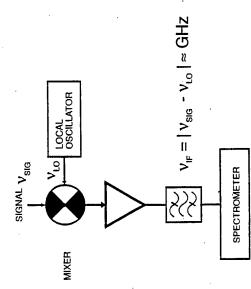
 $500 \, \mu \text{m}$ - < $100 \, \mu \text{m}$ $20 \, \text{cm}^{-1}$ - > $100 \, \text{cm}^{-1}$

2.5 meV - > 12 meV

.

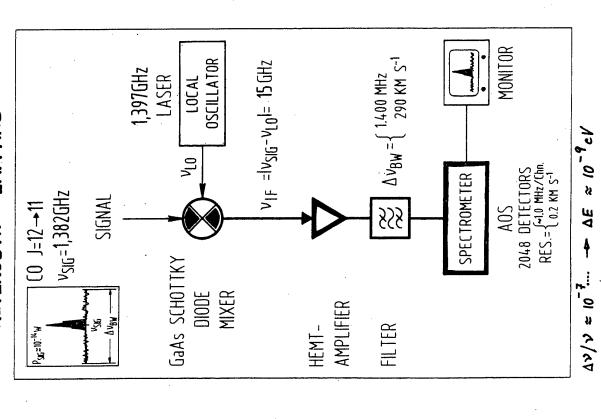
 $v/\Delta v \geq 10^6$

Resolution:

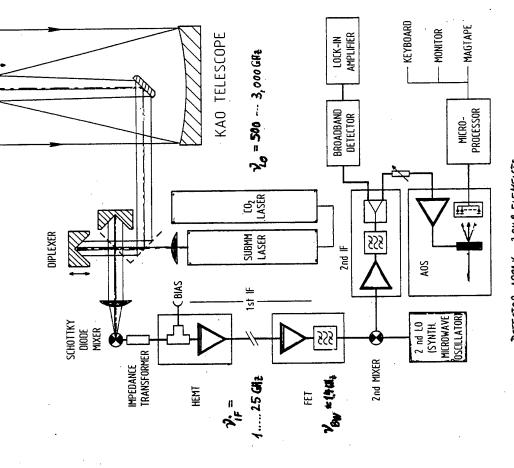




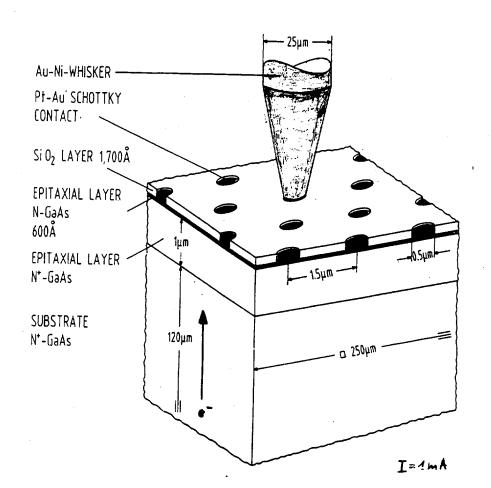
HETERODYN - EMPFANG



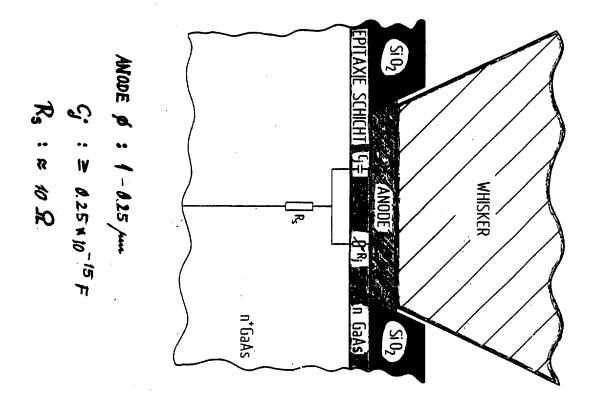
HETERODYNE DETECTION

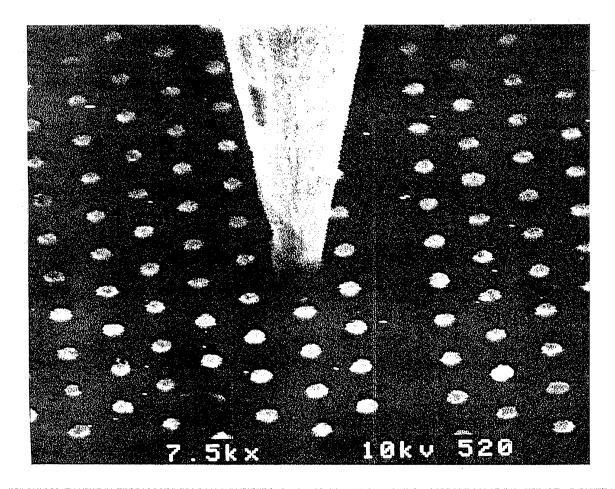


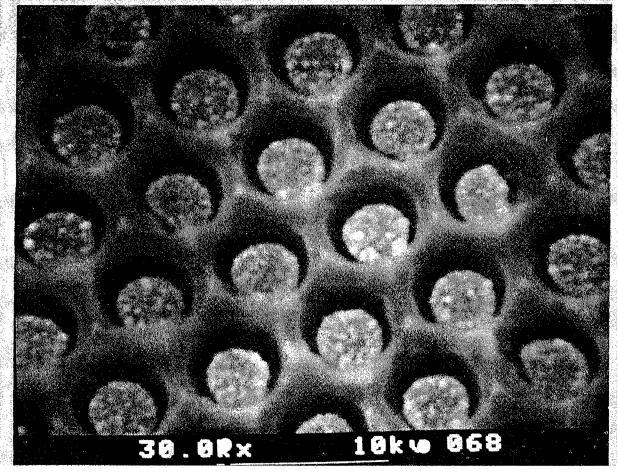
Detector Array 2.048 elements Δ^3_{RES} : 100 kH3/1 MH3 per channel

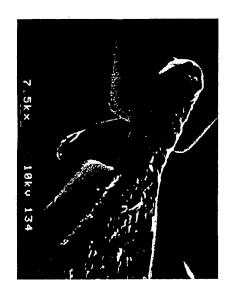


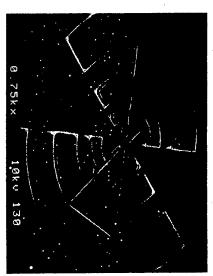
 $\phi \ge 0.25 \,\mu\text{m}$ $C_j \ge 0.25 \,\text{fF} \left[10^{-1} \,\text{R}_s \approx 10 \,\Omega\right]$









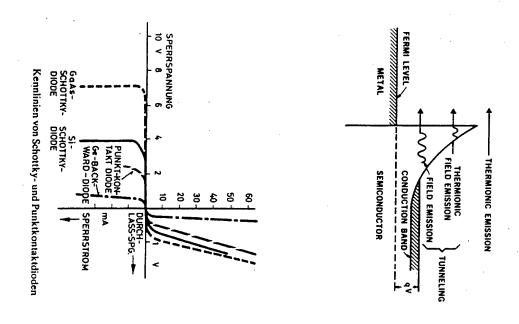


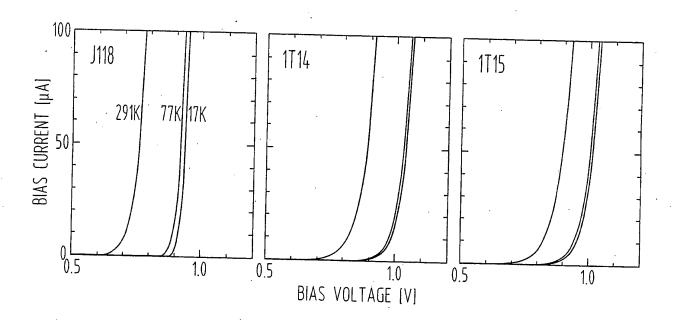


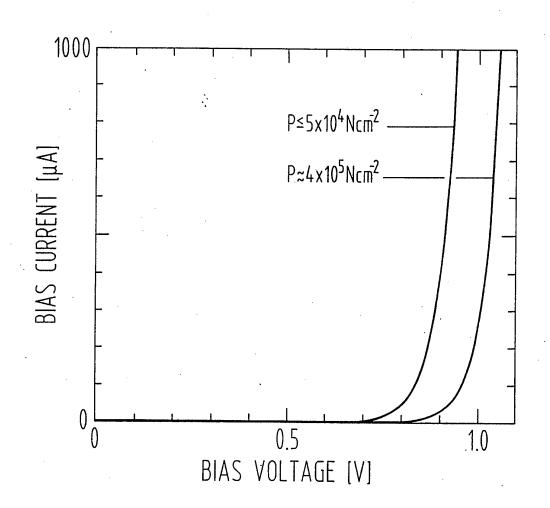
DIODE	J 118	117	1 I 12	1 T 15	
ANODE DIAMETER [µm]	1.0	0.8	0.45	0.25	
EPITAXIAL LAYER THICKNESS D _{epi} [Å]	1,000	1,000	600	~300	
DEPLETION THICKNESS AT ZERO BIAS D _{depl} [Å]	~1,000	650	500	~300	
EPITAXIAL LAYER DOPING N _D ·10 ¹⁷ [cm ⁻³]	1.0	3.0	4.5	10	
CAPACITY AT ZERO BIAS C _{j0} [fF]	1.8	0.9	0.45	0.25	
SERIES RESISTANCE R_s $[\Omega]$	30	13	33	~20	

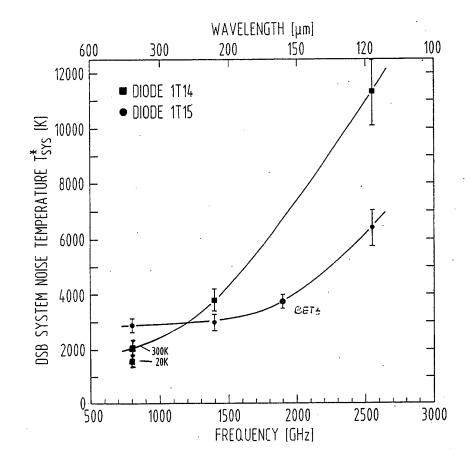
20 - 21TRC

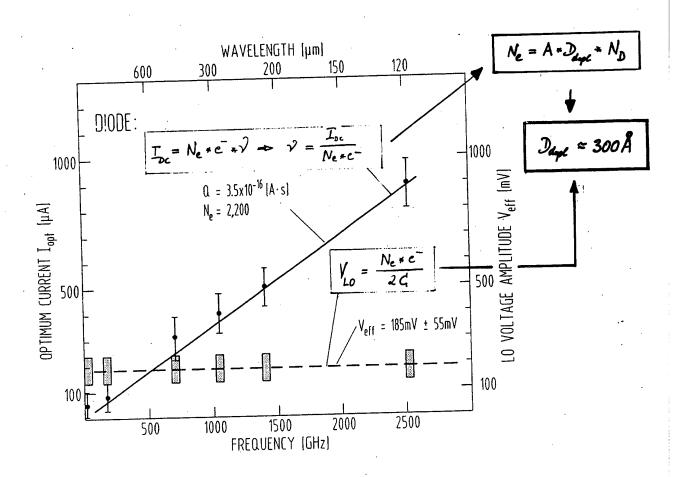
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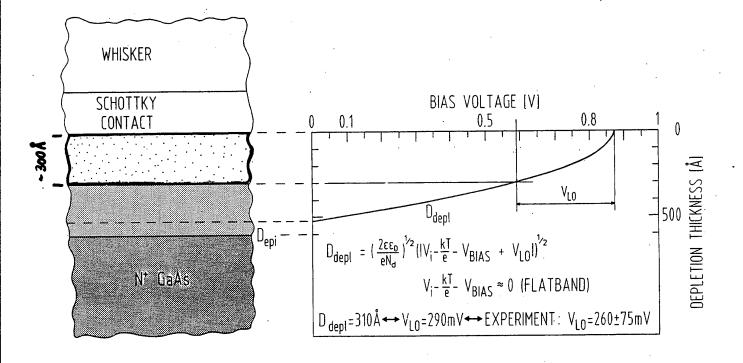










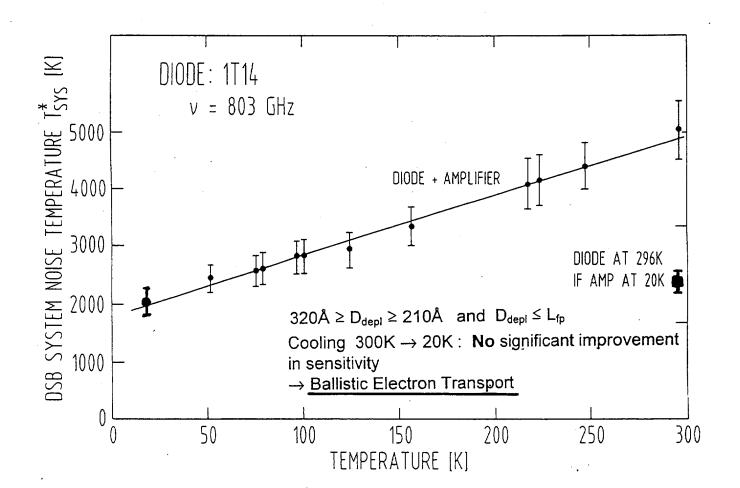


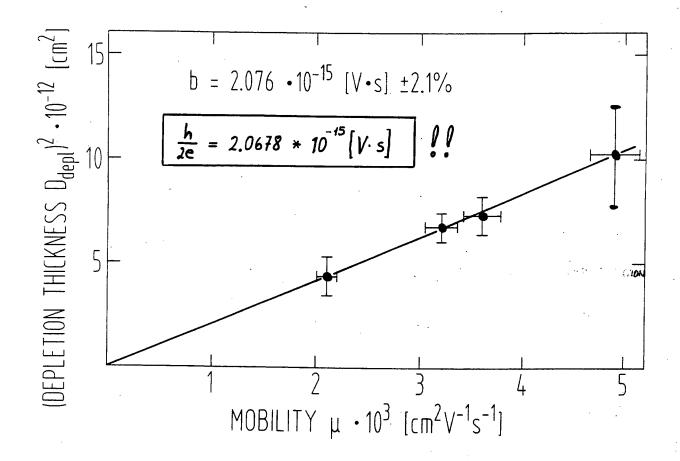
ELECTRON TRANSPORT IN MIXING VOLUME

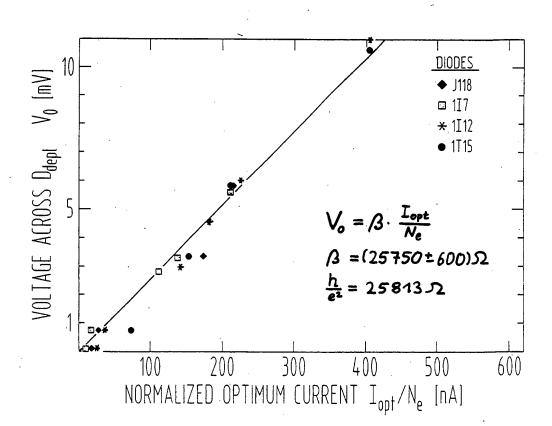
$$I_{opt} = 500 \, \mu A$$
 = 1.6 * 10⁻¹⁹ C * 2,200 * 1.4 * 10¹² Hz $V_{V} = 3 * 10^{15} \, \text{e/sec} = 3 * 10^{15} \, \text{e/se$

_		~1					
GaAs Lattice constant: 5.653	MOBILITY μ [cm²V¹s⁻¹]	MEAN FREE PATH L _p [Å]	RECTIFIED LO SIGNAL V _{LO} [mV]	ACTIVE DEPLETION THICKNESS Dan [Å]	ELECTRONS PER LASER CYCLE N _e	EPITAXIAL LAYER DOPING N _D [10 ¹⁷ cm ³]	DIODE
5.6533Å	4,900	835	70	320	2,800	1.0	J 118
4	3,600	635	160	: 270	4,500	3.0	117
•	3,200	520	260	260	2,200	4.5	1 1 12
•	2,100	350	380	208	1,300	10	1 T 15

Table 2









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1 Introduction

The two points I wish to make are

- 1. Intersubband transitions will be important in the future development of terahertz technology, and
- 2. In order to appreciate, and therefore exploit fully, the physics of intersubband transitions, a detailed theoretical approach needs to be employed.

2 Introduction to Lasers

2.1 Time reversal and stimulated emission

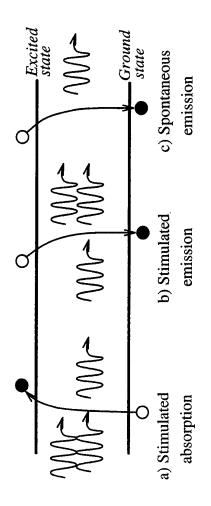


Figure 1: The three optical transitions within a laser

Excited state Ground state c) Spontaneous $A_{2I}N_2$ emission ON_2 $B_{2I}N_2 p(E_{2I})$ b) Stimulated 2.2 Population inversion and light amplification \sim 0 emission $B_{12}^{N_I} p(E_{II})$ O_N a) Stimulated absorption E_{2I}

Figure 2: The three optical transitions within a laser

$$B_{21} = B_{12} \qquad \frac{A_{21}}{B_{21}} = \frac{n_R^3 E_{21}^2}{\pi^2 \hbar^3 c^3} \tag{1}$$

In order for amplification to occur the stimulated emissions must exceed the absorptions, given $B_{21}=B_{12}$ then

$$N_2 > N_1 \tag{2}$$

Population inversion is therefore a necessary condition, but it is not sufficient.

- 2.3 Cavities and coherence
- Cavity
- Spontaneous emission
- Optical feedback
- Stimulated emission
- Amplification
- Gain (threshold condition)
- Lasing
- 2.4 Calculation of Einstein coefficients

Using a 'time dependent perturbation' approach, Mroziewicz (P36) gives

$$B_{12} = \frac{\pi e^2 \hbar}{m_0^2 \epsilon_0 n_R^2 E_{21}} |\langle \Psi_2^*(\mathbf{r}) | \mathbf{p} | \Psi_1(\mathbf{r}) \rangle|^2$$
 (3)

 A_{21} follows as above.

To proceed further requires knowledge of the 'state functions' Ψ .

- 3 Quantum well physics—theory and computation
- 3.1 Assumptions and approximations
- 3.2 Effective mass approximation

In vacuo
$$E = \frac{\hbar^2 k^2}{2m_0}$$
 in a crystal $E = \frac{\hbar^2 k^2}{2m^*}$ (4)

At relatively small wave vectors (k) it is also possible to make the further assumption that the effective mass m^* is constant, i.e. the crystal has parabolic bands.

3.3 Envelope function approximation

Representing the electron by a 'wave function' Ψ then, Ψ must have the same period as the crystal

$$\Psi = e^{i\mathbf{k}\cdot\mathbf{r}}u(\mathbf{k},\mathbf{r}) \tag{5}$$

where the function u has the periodicity of the lattice and is known as a Bloch function, the plane wave component repeats at an integral number of lattice constants.

In the description of localized states the wave functions can be composed of a linear combination of the bulk states above and hence are written,

$$\Psi = \psi(\mathbf{r})u(\mathbf{r}) \tag{6}$$

where the sets of envelope functions ψ and Bloch functions u are both orthonormal. Generally the properties of quantum wells can be expressed in terms of just the more readily calculated envelope function ψ , thus simplifying the problem consid-

3.4 Form of the kinetic energy operator

The quantum mechanical linear momentum operator is given by

$$\mathbf{p}_z = -i\hbar \frac{\partial}{\partial z} \tag{7}$$

 $\mathbf{p}_z=-i\hbar\frac{\partial}{\partial z} \eqno(7)$ Generally is is accepted that the kinetic energy operator is given by

$$\mathcal{T} = \frac{1}{2} \mathbf{p}_z \frac{1}{m} \mathbf{p}_z \tag{8}$$

Recently, it has been demonstrated that, the correct operator should be

$$\mathcal{T} = \frac{1}{2} \frac{1}{\sqrt{m}} \mathbf{p}_z^2 \frac{1}{\sqrt{m}} \tag{9}$$

For now we will avoid the issue by assuming that the tures, this is a good approximation in $GaAs/Ga_{1-x}Al_xAs$ effective mass is constant across the quantum well strucstructures with low x.

3.5 Solution of one-dimensional quantum well potentials

Under the envelope function and effective mass approximation the Schrödinger equation is of the form

$$-\frac{\hbar^2}{2m^*}\frac{\partial^2}{\partial z^2} + V(z)\bigg)\psi(z) = E\psi(z) \tag{10}$$

The Transfer Matrix Technique:

$$\psi(z) = A\cos(kz) + B\sin(kz), \qquad E > V(z) \quad (11)$$

$$\psi(z) = A \exp(\kappa z) + B \exp(-\kappa z), \qquad E < V(z) \tag{12}$$

 \mathbf{where}

$$\kappa = \sqrt{\frac{2m^*(V(z) - E)}{\hbar^2}} \tag{13}$$

 $k = \sqrt{\frac{2m^*E}{\hbar^2}}$

as $z \longrightarrow \pm \infty$ then in the simplest structure, the single Recalling the standard boundary conditions $\psi(z) \longrightarrow 0$ quantum well, the wavefunction is as below:

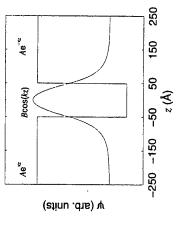


Figure 3: Transfer matrix solution

$$k \tan\left(\frac{ka}{2}\right) = \kappa$$
, where a is the well width

(14)

3.6 Numerical solution of arbitrary potential

Using the standard finite difference expansion

$$\frac{d^2 f}{dx^2} = \frac{f(x+\delta x) + f(x-\delta x) - 2f(x)}{(\delta x)^2} \tag{15}$$

then the Schrödinger equation can be rewritten as

$$\psi(z+\delta z) = \left(2(\delta z)^2 \frac{m^*}{\hbar^2} (V(z) - E) + 2\right) \psi(z) - \psi(z-\delta z)$$
(16)

and is now in the form of a 'shooting equation'.

This is solved by choosing the starting conditions of the energy E until the standard boundary conditions are exponential growth in the left hand barrier and varying satisfied, i.e.

$$\psi(z) \longrightarrow 0$$
 as $z \longrightarrow c$

(17)

Device Physics of Intersubband Lasers

An example of the implentation of this numerical method is given below.

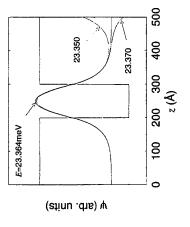


Figure 4: 'Shooted' wave function for energies around solution

3.7 In-plane solutions

The in-plane potential is zero and hence the solutions are plane waves and the total energy is

$$E + \frac{\hbar^2 k_{\parallel}}{2m^*} \tag{1}$$

4 Physics of interband devices

In a bipolar (electrons and holes) device, the quantum well has energy levels in both the conduction and valence bands. These are generally represented schematically as:

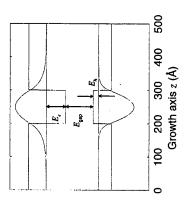


Figure 5: Interband recombination in quantum well structures

4.1 Interband recombination

$$h\nu = Egap + E_e + E_h \tag{19}$$

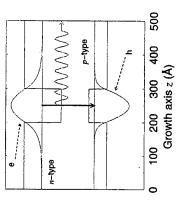


Figure 6: Interband recombination in quantum well structures

4.2 Effect of electric field F

tential profiles, hence to model working devices it is nec-The electric field necessary to produce current injection into the device tilts the conduction and valence band poessary to account for this in the solution of the Schödinger equation

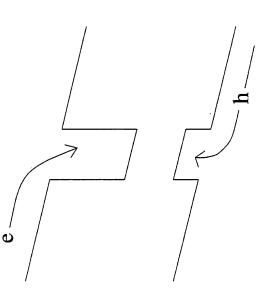


Figure 7: 'Tilting' of bands under an electric field

In principle the Transfer Matrix Technique can be implemented again, however the solutions are no longer linear combination of exponential and trignometric functions.

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Making the substitution

$$y = \left(\frac{2m^*}{\hbar^2}\right)^{\frac{1}{3}} \left[\frac{(V(z) - E)}{(e|\mathbf{F}|)^{\frac{1}{3}}} - (e|\mathbf{F}|)^{\frac{1}{3}}z\right]$$
(20)

allows the Schrödinger equation to be expressed in the

$$\frac{\partial^2 \psi}{\partial y^2} - y\psi = 0 \tag{21}$$

which has a general solution

$$\psi(y) = AAi(y) + BBi(y) \tag{22}$$

Alternatively the potential due to the electric field $(-e\mathbf{F}z)$ can be added to V(z) in Eq. 16 and solved using the same program

4.3 Interband transition rates and selection rules

perturbation H'_{if} causing transitions between electronic Considering the electromagnetic field as a time dependent energy levels, then the transition rate is given by Fermi's

$$W_{i \to f} = \frac{2\pi}{\hbar} |H'_{if}|^2 \delta(E_i - E_f - \hbar \omega)$$
 (23)

Using the envelope function formalism applied to quantum wells, i.e. $\Psi(\mathbf{r}) = u(\mathbf{r})\psi(z)$,

$$H'_{if} = \frac{eA_0}{2m_0} \left\{ \langle u_f | \hat{\mathbf{e}} \cdot \mathbf{p} | u_i \rangle_{\text{cell}} \langle \psi_f | \psi_i \rangle + \langle u_f | u_i \rangle_{\text{cell}} \langle \psi_f | \hat{\mathbf{e}} \cdot \mathbf{p} | \psi_i \rangle \right\}$$

where $\hat{\mathbf{e}}$ is the unit polarization vector and $\mathbf{p} = -i\hbar\nabla$ is the momentum operator.

In the case of interband transitions

$$\langle u_f | u_i \rangle_{\text{cell}} = \int_{\text{cell}} u_f(\mathbf{r}) u_i(\mathbf{r}) d\mathbf{r} = 0$$
 (29)

Therefore

$$|H_{eh}|^2 = \left(\frac{eA_0}{2m_0}\right)^2 |\langle u_h | \hat{\mathbf{e}}.\mathbf{p} | u_e \rangle|^2 |\langle \psi_h | \psi_e \rangle|^2 \tag{26}$$

The last factor is known as the overlap integral between the envelope functions

$$\langle \psi_h | \psi_e \rangle = \int_{-\infty}^{+\infty} \psi_h(z) \psi_e(z) dz$$
 (27)

and determines which optical transitions within the quantum well are allowed.

For symmetric quantum wells transitions are allowed between states of the same parity,

$$E2\longrightarrow H2$$

5 Quantum well subbands

5.1 Higher levels

As the majority of work to date has been on the physically simpler n-type systems, then for this introduction we will focus our attention on the conduction band:

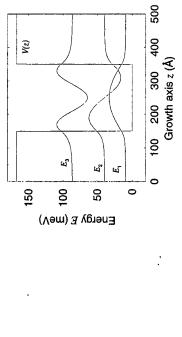


Figure 8: Ground and higher electron states in the conduction band of a quantum well

The higher energy solutions E_2 , E_3 , etc are called 'sub-bands' as they originate from conduction band states of the bulk crystals.

4.4 Interband lasers

- p-n junction
- heterostructure laser (cladding by a higher band gap material produced efficiency gains by means of increased injected carrier and 'optical' confinement)
- quantum well lasers (separate confinement), higher efficiency and low threshold current

The dominant recombination method, i.e. the lasing mechanism, in all quantum well diode lasers is electronhole plasma.

5.2 Intersubband transitions

Recalling equation 24

$$H'_{if} = \frac{eA_0}{2m_0} \left\{ \langle u_f | \hat{\mathbf{e}}.\mathbf{p} | u_i \rangle_{\text{cell}} \langle \psi_f | \psi_i \rangle + \langle u_f | u_i \rangle_{\text{cell}} \langle \psi_f | \hat{\mathbf{e}}.\mathbf{p} | \psi_i \rangle \right\}$$
(28)

but

$$\langle \psi_f | \psi_i \rangle = \int_{\text{all space}} \psi_f(\mathbf{r}) \psi_i(\mathbf{r}) \ d\mathbf{r} = 0$$
 (29)

Therefore

$$H'_{if} = \frac{eA_0}{2m_0} \langle u_f | u_i \rangle_{\text{cell}} \langle \psi_f | \hat{\mathbf{e}}_{\cdot \mathbf{p}} | \psi_i \rangle \tag{30}$$

Now ψ are functions of z only.

This implies that transitions are only allowed when there is a component of the polarization vector $\hat{\mathbf{e}}$ along the growth z-axis.

No intersubband absorption occurs for normal (along the growth z-axis) incident light.

5.3 Consequences of perpendicular polarization

The natural device geometry for optical detectors, and optically stimulated lasers would be based upon normal incidence excitation. However the Brewster angle geometry has had to be adopted.

There are however exceptions in the n-type system:

- anisotropic effective mass,
- spatial dependence of the effective mass and the band non-parabolicity

Emitting devices naturally produce polarized radiation which leaves the sample at the edges, this allows for fabrication into simple edge emitters.

5.4 Intersubband transitions selection rule

In a symmetric system, $\partial \psi/\partial z$ is of opposite parity to ψ , hence the factor

$$\langle \psi_f | \hat{\mathbf{e}}.\mathbf{p} | \psi_i \rangle = -i\hbar \hat{\mathbf{e}}_z \left\langle \psi_f \left| \frac{\partial \psi_i}{\partial z} \right\rangle$$
 (31)

becomes zero for ψ_i and ψ_f of the same symmetry parity, i.e. $\psi_i \longrightarrow \psi_f$ is forbidden.

Representing |i-f| as Δn ,

$$\Delta n = 1, 3, \dots \tag{32}$$

This can be overcome by introducing an asymmetry into the system, either with the application of an electric field, or structurally.

6 Non-radiative mechanisms

6.1 Phonons

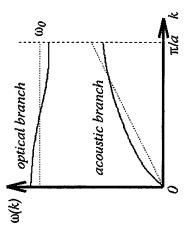


Figure 9: Acoustic ($\omega \propto k$) and optical ($\omega=$ constant) branches in a one-dimensional diatomic lattice

- Upper optical branch: \$\leq 1\$ ps, 36 meV for GaAs, particularly important for intersubband events.
- Lower acoustic branch: ≥ 100 ps, small momenta and energy, important for intrasubband relaxation of warm carriers

6.2 Competing mechanisms

In this example $E_{LO} < h\nu$. An electron initially in the 2nd subband can relax (lose in-plane momentum) by emitting both LO and acoustic (AC) phonons.

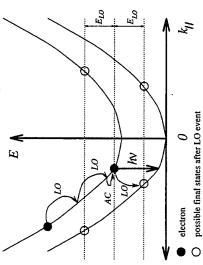


Figure 10: Acoustic phonon, LO phonon and optical scattering for a two conduction subband system

For optical emission the desired photon $h\nu$ emission must compete with the undesired intersubband LO phonon emission.

6.3 Calculation of phonon transition rates

Again using Fermi's Golden Rule, as in equation 23,

$$S(\mathbf{p}, \mathbf{p}') = \frac{2\pi}{\hbar} |H_{p'p}|^2 \delta \left(E(\mathbf{p}') - E(\mathbf{p}) - \hbar \omega \right) \tag{33}$$

Note the properties of the δ -function imply energy conservation.

The transition rate for Polar Optic phonon scattering with a 2D distribution of electrons is

$$S(\mathbf{p}, \mathbf{p}') = \frac{\pi e^2 \omega_0}{\epsilon_s \beta^2 \Omega} \left(\frac{\epsilon_s}{\epsilon_\infty} - 1 \right) \left(N_0 + \frac{1}{2} \mp \frac{1}{2} \right) \times$$

$$\delta \left(\mathbf{p}_{\parallel}' - \mathbf{p}_{\parallel} + \hbar \beta_{\parallel} \right) |G(\beta_z)|^2 \delta \left(E(\mathbf{p}') - E(\mathbf{p}) - \hbar \omega \right) \quad (34)$$

The 'scattering rate' $\frac{1}{\tau}$ is obtained by summing the transition rate S over all possible final states.

Note that the scattering rates are often used in rate equation analysis employed to describe the carrier populations—see later.

7 Intersubband electroluminescence

If a population inversion isn't attained then the device can still give incoherent radiation, this is called electroluminescence.

First demonstrated by Helm at low temperatures and from a subband spacing below the optical phonon energy.

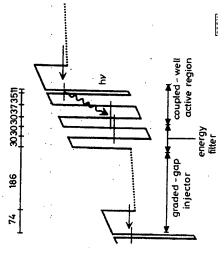


Figure 11: Band diagram of electroluminescent diode at 100 kV/cm

 $(5\mu m)$, generated by a subband spacing greater than the Faist at al., Electronics Lett. **29** 2230 (1993), demonstrated the first electroluminescence in the mid-infrared LO phonon energy and at room temperature.

8 Infrared intersubband lasers

taneous spontaneous emission had been observed in a GaAs-AlGaAs quantum well, by Helm, to that date an West, in September 1993, stated that although instanintersubband infrared laser had not been developed.

Soon after, came the first report of such a laser, referred to as the 'Quantum Cascade Laser', Faist, Capasso, Sivco, Sirtori, Hutchinson and Cho, Science 264 553 (1994). This gave a peak power of 8 mW at a wavelength of 4.2 μ m (71 THz).

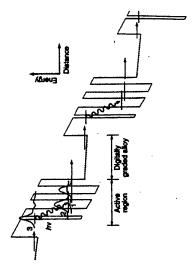


Figure 12: The 'Quantum Cascade Laser', Faist et al.

The lasing action was confirmed by the dramatic line narrowing above a certain current (the 'threshold current').

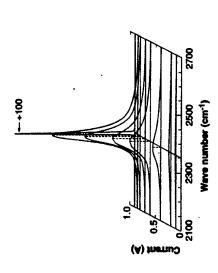


Figure 13: Emission spectrum of the quantum cascade laser at 10 K

As shown previously, the spontaneous emission and the laser radiation were polarized normal to the the layers. For an early review of infrared intersubband lasers see

Yang, Superlatt. Microstruct. 17 77 (1995)

Vertical transition intersubband lasers

- less sensitive to interface roughness, impurity fluctuations,
- therefore exhibit a narrower gain spectrum and a lower threshold.

Faist et al Appl. Phys. Lett. **66** 538 (1995)

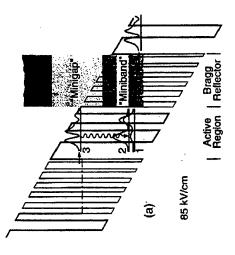


Figure 14: Vertical transition quantum cascade laser with Bragg confined excited state, Faist et al.

- $E_3 \longrightarrow E_2 (271 \text{ meV} \sim 4.5 \mu\text{m}) \text{ was } 1.8 \text{ ps}$
- $E_2 \longrightarrow E_1 \ (30 \text{ meV}) \ 0.6 \text{ ps}$

This has led to pulsed operator up to 100 K, with a threshold current density of 3 kA/cm^2 and a slope efficiency of 300 mW/A.

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10 Longest wavelength intersubband lasers—so far

subband laser to date is only 8.4 μ m, also by Sirtori, et Although intersubband light-emitting-diodes have been reported in the 8-13 μm wavelength region, Sirtori, Ca-Phys. Lett. 66 4 (1995), the longest wavelength interpasso, Faist, Sivco, Hutchinson, and Cho, et al. Appl. al., Appl Phys. Lett. **66** 3243 (1995).

11 A dynamical advantage in moving to Terahertz

Quite simply the photon energy of terahertz frequencies is below that of the dominant loss mechanism, i.e. nonradiative LO phonon emission. Hence merely working at these frequencies eliminates the most detrimental physi-

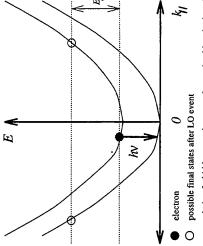


Figure 15: LO phonon emission forbidden near bottom of second subband when $E_2-E_1=h\nu < E_{LO}$

In GaAs the LO phonon energy is 36 meV which is equivalent to a photon frequency of 8.7 THz $(34 \mu m)$.

12 Optically pumped 3-level terahertz (far-infrared) laser

As with any new laser, the simplest route to lasing is via optical stimulation rather than electrical injection.

Within this frequency range the most convenient optical pump is the $10.6\mu m$ CO₂ laser.

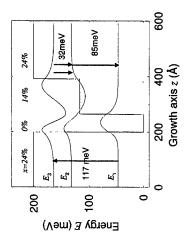


Figure 16: Optically pumped 3-level laser operating at $\approx\!\!7.7$ THz (32 meV, 39 $\mu\mathrm{m})$

The simplest device proposal is the asymmetric quantum well proposed by Berger, Semicond. Sci. Technol. 9 1493 (1994), for the $GaAs/Ga_{1-x}Al_xAs$ system.

12.1 Structural tunability for access to other frequencies

Just varying the structural parameters of the step the design can be tailored across the Terahertz range as desired, whilst keeping the pump energy equal to the CO₂ laser line.

$E_3-E_2({ m THz})$	12.1*	11.1*	9.9*	8.8*	7.7	6.5	5.2	4.0	2.8
$E_3 - E_2(\mathrm{meV})$	49.851	45.708	41.119	36.504	31.750	26.695	21.684	16.612	11.454
$E_3-E_1(\mathrm{meV})$	116.988	117.321	117.117	117.154	117.179	116.899	116.902	116.992	117.143
Step width (A)	101	105	111	118	127	140	157	182	224
Step x (%)	10	11	12	13	14	15	16	17	18

Table 1: Structural parameters of step in an asymmetric quantum well with a Terahertz $E_3 \longrightarrow E_2$ intersubband separation

Note the designs marked * have a spacing greater than the LO phonon energy of 36 meV, hence the dynamics of their operation will be considerably different from the others.

13 Rate equation analysis

Consider the lower laser level, level 2, of the optically pumped 3-level terahertz laser above.

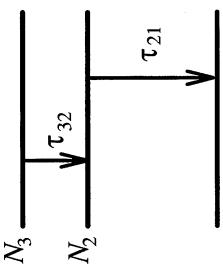


Figure 17: Rate equation analysis of population of 2nd level

$$\frac{dN_2}{dt} = +\frac{N_3}{\tau_{3\to 2}} - \frac{N_2}{\tau_{2\to 1}} \tag{37}$$

where the mean relaxation times τ are inversely proportional to the total scattering rates which include both radiative (optical) and non-radiative (phonon) mechanisms.

$$\tau_{3\to2} > \tau_{2\to1} \tag{38}$$

12.2 Optimization of optical properties

occur for structural parmeters with which the product of the pump absorption efficiency and the lasing output Berger proposed that the optimal band structure would efficiency was maximized.

$$\langle \Psi_f | \mathbf{p} | \Psi_i \rangle = i m \omega_{fi} \langle \Psi_f | z | \Psi_i \rangle \tag{35}$$

Then Berger's result can can be summarized as the structure with which

$$\delta^2 = \langle \psi_3 | z | \psi_2 \rangle \langle \psi_1 | z | \psi_3 \rangle \qquad \text{is maximum} \qquad (36)$$

At equilibrium $\frac{dN_2}{dt} = 0$, for lasing $N_3 > N_2$ hence $\tau_{3\rightarrow2} > \tau_{2\rightarrow1}$

Department of Electronic & Electrical Engineering, University of Leeds, LS2 9JT, U.K.

14 Highest working temperature of an intersubband laser

To date is the **210 K** in *pulsed* mode, and **110 K** in continuous wave mode, of Sirtori et al. Appl. Phys. Lett. **68** 1745 (1996).

In the systems of interest here, the in-plane dispersions of the conduction subbands will be parallel, hence the broadening of the population in the upper state shouldn't have too much of a detrimental effect on the laser linewidth as the optical transitions are vertical (small momentum transfer) between the parallel bands.

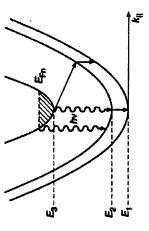


Figure 18: In-plane dispersion curves for conduction subbands, diagram from Faist, Science

This phenomena does not occur in interband recombination, since the conduction and valence bands have quite different parabolicities (effective masses).

15 Other materials

The LO phonon energy in GaAs is 36meV and this puts an upper limit of 8.7 THz on the devices.

Maximum frequency (THz)	2	80	10	10	12	12
aterial LO phonon energy (meV)	30	36	42	43	50	50
Material	InAs	GaAs	AISb	InP	AIAs	GaP

Table 2: LO phonon energies in selected III-V materials, Landolt and Bornstein, Vol 21

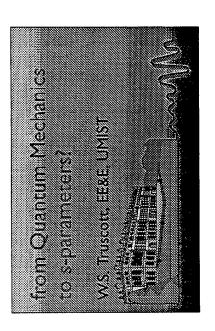
If room temperature operation proves difficult to achieve for frequencies below kT, then another avenue could be to restrict the frequency ν range to

$$kT < \nu < E_{LO}$$

which would retain the benefit of working below the LO phonon energy.

16 and finally...for completeness

eration based on LiNbO₃ crystals pumped by a Nd:TAG suo Taniuchi, and Hiromasa Ito, Appl. Phys. Lett. 68 An alternative technology is available for terahertz genlaser, see for example, Kodo Kawase, Manabu Sato, Tet-2483 (1996).



Acknowledgements

- ► UMIST research group
- -P.D. Buckle, M.A. Lynch, C-Y. Kuo
 - -P. Dawson, M. Missous
- ▼ Colleagues
- -J. Lowell, K.E. Singer
- ► from an original idea by
- -M. Büttiker and R. Landauer

Overview

- ► Introductions
- Some semiconductor device physics
- ► When do we need quantum mechanics?
- ► Solutions to Schrödinger's equation in ac fields
- ► Consequences of solutions
- ► What can be calculated
- ► Self-consistency
- ► Summary and Conclusions



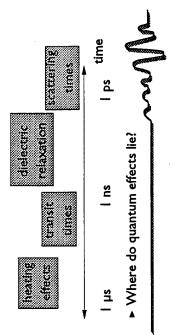
Aims of this lecture

- ► To discover when devices need to be described by quantum mechanics
 - ► To outline the extent to which the electrical characteristics of devices can be calculated starting from quantum mechanics



The Art of Device Physics

► Choose best length and time scale to describe device operation



Quantum Transition Devices

- ► Transitions between two electron states:
- band-band LEDs, LASERs, photodiodes
- -inter sub-band quantum cascade laser, detectors
 - -wavelengths 0.5 µm 10 µm
- ► Only one photon per electron transition
- Power to current ratio (W/A) $\propto 1/\lambda$
- ► Spontaneous emission (LEDs) requires:
- charge motion

 half wavelength
- for excitons in GaAs: 25 nm ≡ 80 nm



What is Quantum Mechanics?

wavelength \Leftrightarrow momentum $\lambda = h/p$ \Leftrightarrow frequency \Leftrightarrow energy v = E/h

for electrons in GaAs:

i THz ⇔ 4 meV ⇔ 9 km/s (nm/ps) ⇔ 70 nm



Quantum Transition Devices

- ► Stimulated emission (LASERs) requires:
- optical (electromagnetic) waveguiding
- active region at maximum field of guided wave
- high n dielectric waveguiding structures $\equiv 10~\lambda$
 - ► Terahertz LASERs would need:
- stack of 10 100 transitions for good W/A ratio
 - high n dielectric waveguides 300 µm thick
- active region 150 µm below top of guide
- serious growth problems



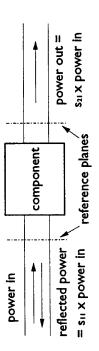
Quantum Transition Devices

- ► Metal structures are a more compact alternative to dielectric waveguides
- Antennas couple to free space e.m. radiation
- waveguides are efficient carriers of e.m. radiation - Transmission lines, coaxial cables and metal
- These are characterised by impedances
- $Z = \sqrt{UC} = E/H$

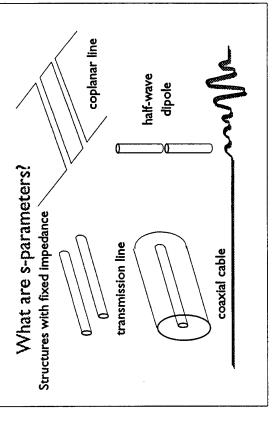


What are s-parameters?

▶ power ratios referred to a fixed impedance transmission line



power reflected not dependent on distance relative phases defined at reference planes



When are electronic devices quantum mechanical?

- ► Drift-Diffusion equation for electrons $J_n = -qD\partial n/\partial x + qn\mu E$
- current density electric field
- diffusivity Ŏ
- mobility
- density of carriers of charge q
- ► no inertia, no quantum mechanics, continuum
- rapid scattering ensures equilibrium velociti

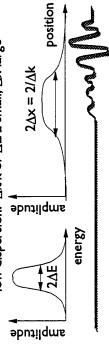


When are electronic devices quantum mechanical?

- ▼ Scattering times
- quantum effects require out » 1
- otherwise waves are always being "measured"
- τ can be estimated from μ : $\mu = q\tau/m$
- for $\mu = 1 \text{ m}^2/\text{Vs}$ (10,000 cm²/Vs) in GaAs
 - f » 0.5 THz v T = 0.35 ps
- electron-phonon scattering strongly temperature dependent
- onset frequency lower in cooled devices

When are electronic devices quantum mechanical?

- ► Wave packets travel at group velocity ∂α/∂k
- for $\omega = E/K = Kk^2/2m$
- v = kk/m = p/m classical velocity
- ► Good description if wave packet stays together
- low dispersion: $\Delta k/k$ or $\Delta E/E$ small, Δx large



When are electronic devices quantum mechanical?

- ▶ Ballistic carriers
- with no scattering steady acceleration
 - $s = ut + \frac{1}{2}at^2 = ut + \frac{1}{2}qEt^2/m$
- for GaAs
- $a = 3 \times 10^{19} \text{ m/s}^2$ for E = 10 MV/m(30 µm/ps² for 10 mV/nm)
- but very fast optical phonon scattering occurs for E > 36 meV (s = 4 nm t = 16 fs)
- ► has inertia, discrete carriers
- ▶ no quantum mechanics

When are electronic devices quantum mechanical?

- ► If wave packet description is valid then carriers can be described by classical ballistics
- Quantum mechanics describes dispersion
- wave packets broaden
 - ¬"chirping"
- Broadening in time t: $\Delta x = t\Delta v = d\Delta v/v$ $\Delta x/d = \Delta v/v = \Delta k/k = 2\Delta E/E$
- ► Wave packets fail for: large ∆E/E; long times; and for k ≠√2mE/h

Time-dependent solutions to Schrödinger's equation

- ► Uniform potential modulation
- adds uniform phase modulation to unchanged wavefunction
- $V(x,t) = V_0(x) + V_1 \cos(\omega t)$
- $\Psi(x,t) = \Psi_0(x,t) \exp[-(iVI/\omega f)]\sin(\omega t)]$

M. Buttiker and R. Landauer, PRL, 49, 1740 (1982)



Fime dependent solutions to Schrödinger's equation

- Uniform field modulation added to linear potential
- Wave function oscillates as a classical particle
- Space dependent phase modulation added
- Phase modulation dependent on Fo and FI
- $ightharpoonup V(x,t) = V_0 F_0x F_1x \cos(\omega t)$
- $\exp[(iF1x/\omega\hbar+iF0F1/m\hbar\omega^3)\sin(\omega t)]$ $\Psi(x,t) = \Psi 0[x + Fi\cos(\omega t)/m\omega^2,t] \times$
- also small second order phase modulation

Time dependent solutions to Schrödinger's equation

- Uniform field modulation added to constant potential
- Wave function oscillates as a classical particle
 - - Space dependent phase modulation added
- $\mathbf{V}(\mathbf{x},\mathbf{t}) = \mathbf{V}\mathbf{0} \mathbf{F}\mathbf{x} \cos(\omega \mathbf{t})$
- exp[(iFx/\alpha\frac{n}{n})sin(\alpha\ta)] $\Psi(x,t) = \Psi0[x+F\cos(\omega t)/m\omega^2,t] \times$
- also small second order phase modulation



Time dependent solutions to Schrödinger's equation

- ► Uniform field modulation added to parabolic potential
- Wave function oscillates as a classical particle in same potential: effective field G= FI/(1- $\omega v^2/\omega^2$)
 - Space dependent phase modulation added
- $ightharpoonup V(x,t) = \frac{1}{2} m\omega^2 x^2 FI \times \cos(\omega t)$
- $\Psi(x,t) = \Psi_0[x + G\cos(\omega t)/m\omega^2,t] \times$
- also small second order phase modulation $exp[(iGx/\omega f)sin(\omega t)]$



Linking exact solutions

- ► At a boundary between time-independent and time-dependent regions
- Ψ and $\partial \Psi/\partial x$ must be continuous
- Match Aexp{ikx-iEt/ħ} +Bexp{-ikx-iEt/ħ} with [Cexp(iκξ)+Dexp(-iκξ)]exp[-iEt/ħ+(iFx/ωħ)sin(ωt)]
- where $\xi = [x+(F/m\omega^2)\cos(\omega t)]$
- ► Expanding exp[iαcos(αt)] and exp[iβsin(αt)] gives [Cexp{irx-iEt/fl}∑i']n[xf/mα²)exp(inαt) +

Dexp{-irx-iEt/h}\overline{\overline{L}}\over

Linking exact solutions

- ► At Energy E + nfm
- From matching Ψ : Bn = $\Sigma[C_m+D_m] \int_{h-m} (\kappa_m F/m\omega^2)$
 - From matching ∂Ψ/∂x:

 $-ikBn = \sum_{i} r^{m} \kappa_m [C_m - D_m] \int_{l^m m} (\kappa F/m\omega^2) + F/\omega \tilde{h}[C_{m-1} - C_{m+1} + D_{m-1} - D_{m+1}]$

In time-independent region additional waves are generated at all harmonics of ω with amplitudes determined by relevant Bessel functions

Linking exact solutions

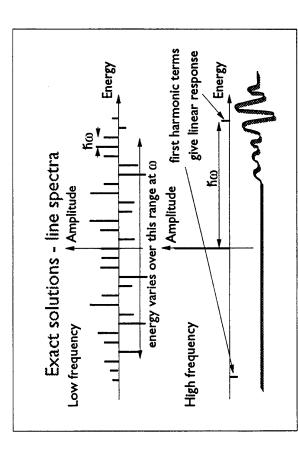
- Match waves with same time dependence
 - ▶ At Energy E
- From matching Ψ : A+B = [C+D] $\int o(\kappa F/m\omega^2)$
 - From matching ∂Ψ/∂x: ik[A-B] =
- $\kappa[C-D] \log(\kappa F/m\omega^2) + [C+D] \partial [\log(Fx/\omega t)]/\partial x$
 - these fix B/A, C/A and D/A [=0

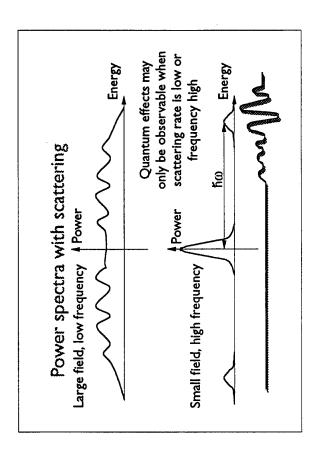
- Source

Linking exact solutions

Device structure with one time-dependent region and incident energy E

	F2 E+3400			F.I. E.hm		F-3 E-3h®	exit region
→ 60	D2	IO	D	D-I	D-7	D-3	time-dependent region
უ '	ឧ	<u>5</u>	o L	<u>ن</u>	7:5 	C-3	time-o
. 83	, B2	, T	B A	B-1	B-2	B-3	incident region





ls quantum mechanics needed?

- Quantum mechanical solutions are same as classical if E ± fm can form a wave packet with E and system is linear with energy over ± fm
- $\hbar\omega/E \ll 1$ and $k(E+\hbar\omega) = k(E) + \hbar\omega\partial k/\partial E$
- ► This will always fail at high enough frequencies
 - Quantum behaviour is possible in many Terahertz devices



Calculation of current flow

- Ist order calculation
- Exit amplitude proportional to
- $F + (F_1 + F_{-1})\cos(\omega t) + i(F_1 F_{-1})\sin(\omega t)$
 - Exit current proportional to

- Monday

Calculation of charge oscillation

- ► 1st order calculation of dipole moment variation
- хь үх*у dx
- $= Xh \Psi (\omega) + V(\omega) + V(\omega) = V + V(\omega) = V(\omega) =$

 $\int [C^* \exp(-i\infty) + D^* \exp(i\infty)] \times \times$

frequency response

reduced high

frequency response

quantum behaviour

K(E+Kw)

negative conductance

power gain

no current modulation

classical behaviour low conductance

Effects of quantum mechanics:

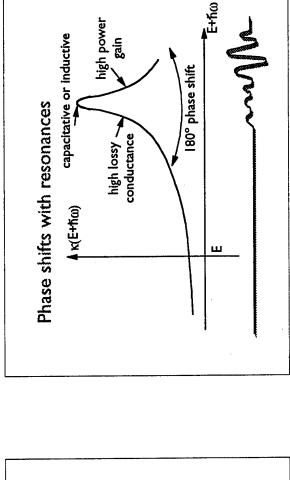
enhanced high

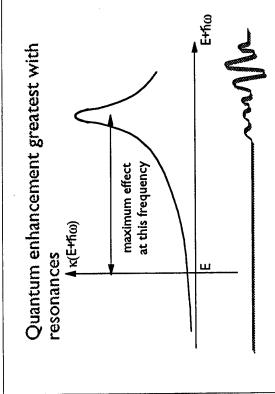
E+fa

high conductance

[Clexp(ikix-iot)+ Clexp(ik:ix+iot) + Dlexp(-ikix-iot) + D.lexp(-ik:ix+iot)]

► This may be interpreted in terms of polarisation





Maximising benefit from resonances

- Frequency of maximum gain depends on incident
- spread of incident energies should match resonance
- use incident energy filter (another resonance)
- Effects scaled by dc current
- High gain requires high current density
- ► Resonances above and below E can enhance both sidebands
- · use three resonances spaced by hou

Summary

- Quantum effects only observed when wave packet description fails
- Quantum effects give a frequency dependent response
- ► Quantum effects can enhance the response above its low frequency value over certain frequency

5

Self-consistency

- ▼ ac solutions
- \bullet $\varepsilon \partial E/\partial x = \rho(x) \sim \Psi * (x) \Psi(x)$
- ▶ but $\chi(\omega) = \partial \rho(\omega)/\partial E(\omega)$ is non-local
- ► continuous variation of E:

 $\varepsilon E(x,\omega) = \varepsilon E(0,\omega) + \int \Psi * (x,\omega) \Psi(x) + \Psi * (x) \Psi(x,\omega) dx$ can be approximated by a series of steps:

 $EE_n(\omega) = EE_{n-1}(\omega) + \int_n \Psi^*(x,\omega) \Psi(x) + \Psi^*(x) \Psi(x,\omega) dx$



Conclusions

- ► At terahertz frequencies semiconductor structures are likely to exhibit quantum effects particularly:
 - if cooled
- if there are resonances
- ▶ s-parameters can be calculated for stuctures showing quantum effects
- calculation of s-parameters very difficult if there are ► But the requirement for self-consistency makes strong quantum resonances



THURSDAY JULY 4



Travelling Wave Detectors: A New Principle for Terahertz Operation

by

H Sigg

(No material available.)

New directions in terahertz technology

Materials issues for new devices

D. Lippens

Institut d'Electronique et de Microélectronique du Nord UMR CNRS 9929 Université des Sciences et Technologies de Lille 59652 Villeneuve d'Ascq Cedex, France Chateau de Bonas, France July 11, 1996



Outline

Low temperature grown GaAs Related compounds Transport properties Non stoichiometric materials Bulk materials Electronic structure Doping issue

p-type doping n-type doping Heterostructure

Single Heterojunction (type I and II)
Material system grown on GaAs substrate
inft-based materials
Quantum well and turnelling heterostructures
Modulation doped heterostructure
Tunneling barrier

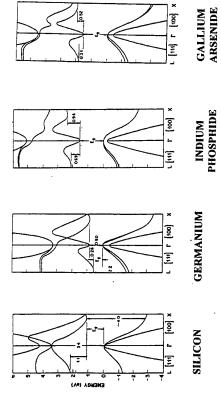
resonant tunneling heterostructure (double barrier and superlattice)

ENERGY BAND STRUCTURE

Parameter		dly	AlAs	AISb	GaP	GaP GaAs GaSb InP InAs	GaSb	InP	InAs	InSb	
Direct Energy Gap (eV)	$\Gamma_{\rm B} - \Gamma_{\rm I}$	3.62 (77K)	3.14	2.22	2.78	1.424	0.70	1.34	0.356	0.180	
Indirect Energy Gap (eV)	F ₁₃ \ X ₁	2.45	2.14	1.63	2.268	-80 4	1.25 (10K)	2.04			
Temperature Dependence	dE	-3.6	-5.2	-3.5	-4.5	-3.9	-3.7	-2.9	-3.5	-2.8	
of Direct and Indirect Energy Gap (X 10 ⁻⁴ eV K ⁻¹)	dEasist		-4.0		-5.2	-2.4		-3.7			
Pressure Dependence of Minimum Energy Gap (X 10-4 eV-1)	dE∫dP			-1.51.6	- I.6	12.0	14.7	80 80	9.01	15.9	
Indirect Energy Gap (eV)	$\Gamma_{13} - L_1$					1.81 (110K)	0.81	1.74			

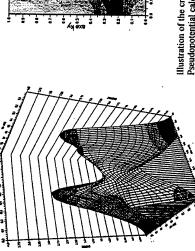
(a) Minimum situated at the Δ axes near the boundary; k=(0.903,0,0) for AlAs; k=(0.95,0,0) for GaP. (b) Temperature dependence of the energy separation between Γ and X minima.

ELECTRONIC STRUCTURE (Bulk materials)



BAND STRUCTURE

•Iso-energy curves for Al_{0.45} Ga_{0.55} As (TXK) •Iso-energy for AlAs first conduction band



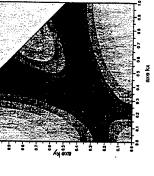
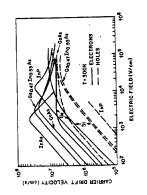
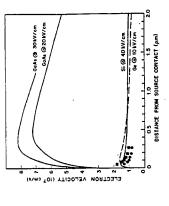


Illustration of the cross-over between Γ and X valley Pseudopotential calculations

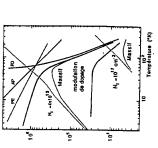
CARRIER VELOCITIES IN III-V COMPOUNDS



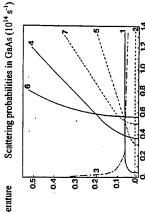


TRANSPORT PROPERTIES

Variation of electron mobility (cm²/Vs) versus temperature



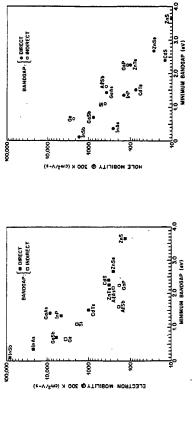
At room temperature
Mobility limited by optical phonon
At low temperature
Mobility limited by impurity scattering



Polar optical phonon(emission)
 Polar optical phonon (Absorption)
 Impurity scattering

4. Intervalley scattering F-X (emission)
5. intervalley scattering F-X
6. F-L emission
7. F-L absorption

LOW FIELD MOBILITIES IN III-V COMPOUNDS

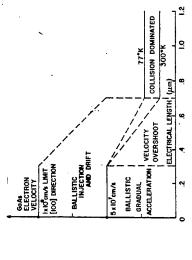


Hole mobilities

Electron mobilities

NON STATIONARY-TRANSPORT EFFECT

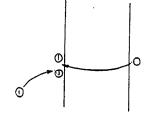
Velocity Overshoot : v= $\mu(B).F$, (E electron energy, F: Electric field) Unbalance between the local energy and the electric field



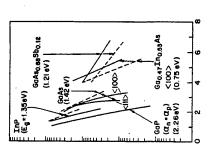
Maximum velocity limited by the band structure (v~ $\partial E/\partial k$) Hot electron injection for high velocity

IMPACT IONIZATION (I)

Energy conditions: E > 1.5 Eg Creation of an electron hole pair



Impact ionization probability (cm⁻¹)



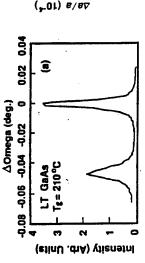
Avalanche condition: Multiplication coefficient $\rightarrow \infty$; $\int \alpha dx = 1$

1/E (10⁻⁶ cm/V)

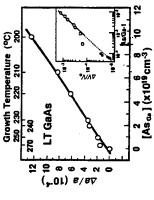
NON STOCHIOMETRIC MATERIALS

Low-temperature growth of GaAs (200°C < Tgrowth <250°C)

Main advantage: Excess arsenic (typically 1%) by preserving the crystal quality



XR Diffraction evidence of an increase in the lattice constant

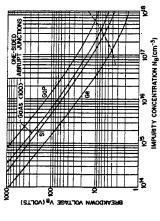


High concentration of As antisites (As_{Gn})

IMPACT IONIZATION (II)

Order of magnitude of avalanche breakdown voltages (Vb)

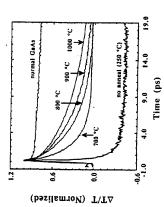
Variation of Vb as a function of Doping concentrations for abrupt junctions, SM. Sze and G. Gibbons Appl. Phys. Lett. 8, 11(1966)



Approximate universal expression $Vb=60~(Eg/1.1)^{3/2}~(Nb/10^{16})^{3/4}$ $Vb=6V~for~ln_{0.5}Ga_{0.7}As_{s}$, $2V~for~lnAs~and~Nb=1_X10^{17}~cm^{-3}$

LOW TEMPERATURE GROWN GAAS

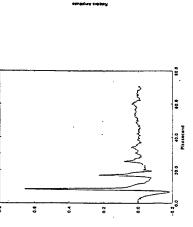
Short life time of photo-excited carriers

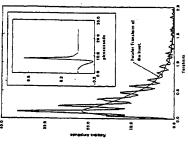


Due to the high concentration of defects, possibility of conduction by hopping process Annealing of material: formation of As precipitates which act as micro Schottky's increasing the resistivity

APPLICATION IN ULTRA-FAST ELECTRONICS

Use of Photoconducting antenna and Electro-optic sampling





Subpicosecond terahertz pulse generation

Fourier transform

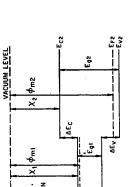
HETEROJUNCTION

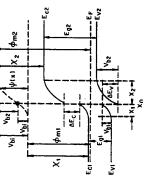
Basic Model

After Anderson Solid State Electronics, 5, 341, 1962

Ideal aniso-type heterojunction

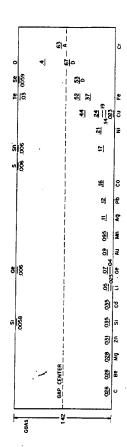
Energy band Diagram for two isolated SC





DOPING ISSUE

Measured ionization energies for various impurities in GaAs

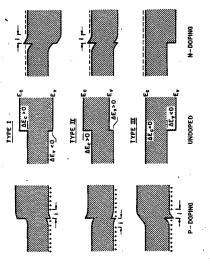


N-type doping: essentially Silicon

Typical doping level in GaAs : 2x10¹⁸cm⁻³ for GaAs, 5x 10¹⁸ cm⁻³ for In _{0.53} Ga_{0.47} As material

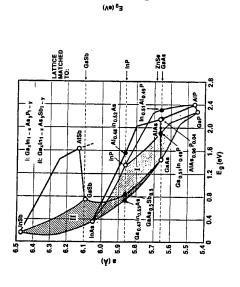
P-type doping:
Mg, Be, Zn
More recently systematic use of Be for low diffusion properties

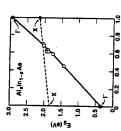
POSSIBLE HETEROSTRUCTURE BAND ALIGNMENTS



CHOICE OF A LAYERED STRUCTURE

Variation of the band gap as a function of lattice constant for III-V binary and alloy semiconductors

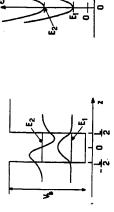




EIGENSTATES and DENSITY OF STATES

2 D confinement of electron or holes

2D density of states dispersion along the kx direction Envelope wavefunction







For a two-dimensional system, the density of states exhibits a stair-like evolution with

ELECTRONIC BAND PARAMETERS

AlxGal-xAs Ternary alloys

 $\begin{array}{l} Al_xGa_{1,x}As\\ 1.42+1.247\ x \ (0< x<0.45)\\ 1.9+0.125x+0.143\ x^2\\ 0.45< x<1 \end{array}$ Band gap energy GaAs AlAs 1.42 Egr 2.16 Egx

Conduction band effective mass really 0.067 0.14

Band gap discontinuity average values $\Delta Ec/\Delta Eg = 60:40$

AlinAs-GainAs heterostructure

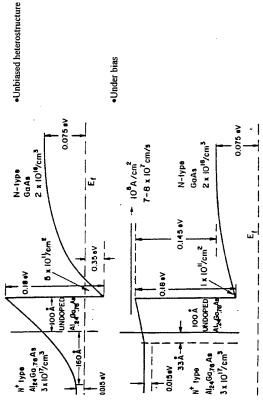
AllnAs 1.47 0.075 InGaAs 0.76 0.042 ∆Ec = 0.55 Band gap energy Effective mass Conduction band offset

AlGaAs-GaInAs strained layers

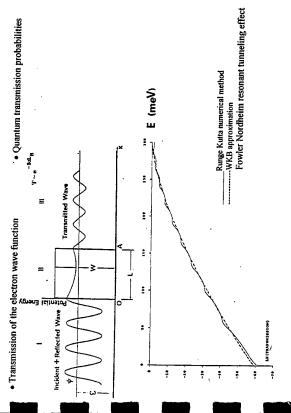
 $\begin{array}{ll} 0.042 & 0.14 \\ \Delta E c = 1.2 \text{ for the } F\text{-band} \\ \Delta E c = 0.65 \text{ for the } X\text{-band} \end{array}$ Lattice matched on InP Ino.53 Gao.47As Al. 0.76 3 E Band gap energy Effective mass Conduction band offset

Energy in eV

SINGLE HETEROJUNCTION



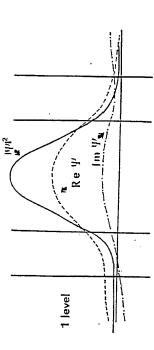
TUNNELING BARRIER



DOUBLE BARRIER HETEROSTRUCTURE (Resonance effect)

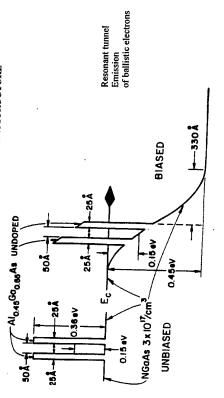
Constructive interference when the electron wavelength matches the well dimension

Quantum transmission probability (T)



At resonance T#I, $T\sim T_gT_d$ under off-resonance conditions With T_g and T_d the transmission of the left and right barriers

RESONANT TUNNELING HETEROSTRUCTURE

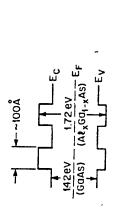


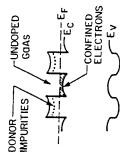
The double barrier heterostructure acts as an energy filter

SUPERLATTICE STRUCTURE

•Energy band diagram for undoped superlattice GaAs/Al_{0.3}Ga_{0.7}As heterostructure

•For Modulation doped heterostructure Dingle et al. Appl. Phys. Lett. 33, 665 (1978)



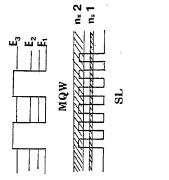


Real space transfer of electrons and band bending by space charge effect

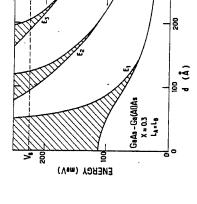
MULTI-QUANTUM WELL (MQW) AND SUPERLATTICE (SL)

Transition between MQW and SL

·Calculated subband energies as a function of period d



Envelope wave function approximation G. Bastard Phys. Rev. B24(1981) 5693



HETEROSTRUCTURE

As a general rule:

Good Schottky contact on large band gap-undoped material such as n-GaAs

Good Ohmic contact on low gap-highly doped semiconductor such as InGaAs with large Indium content

trade-off alleviated by the use of heterostructures

A crystalline Potential barrier permits:

•to confine the carriers by means of a quantum well on short scale ightarrow a room temperature operation

•to block the carriers in order to induce depleted zones with capacitance modulations (varactor effect)

•to fabricate high transmissivity tunneling barriers without the requirement of a high doping concentration

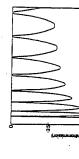
to modify the density of states

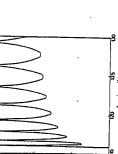
However we have to distinguish between the intrinsic and extrinsic properties and some design rules are comparable to those of conventional devices Transit time limited devices (Gunn diodes and superlattice diode with negative differential resistance effect) RC time constant (Esaki-tunnel diode and Resonant tunneling diode)

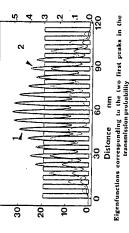
WAVEFUNCTIONS IN SUPERLATTICE

Transmission probability versus energy

Eigenstates
 At equilibrium



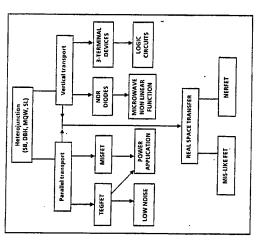




Miniband electron transport

ΔE: miniband width; d superlattice period Condition for localization F > AE/qd

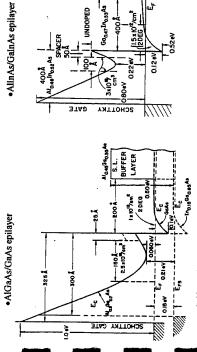
FAMILY TREE OF HETEROJUNCTION DEVICES



Transverse Electron Gas Field Effect Transistor NDR: Negative Differential Resistance

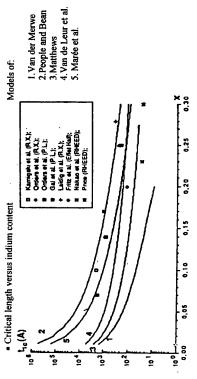
MODULATION DOPED HETEROSTRUCTURE

Real space transfer between a large band gap highly doped region and a low band gap undoped region Illustration of band bending resulting from charge accumulation



Self-consistent solution of the Schrödinger-Poisson equations

CRITICAL LENGTH FOR STRAINED LAYER



Also, the possibility to grow InAs islands self-organized on GaAs substrate for fabricating quantum dots was Recently, the idea of compensated layers (tensile-compressive) has been used. demonstrated

PSEUDOMORPHIC GROWTH

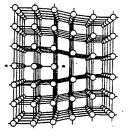
Compressive strain

tensile strain

edge dislocation







InxGa1-xAs on GaAs (x<0.25);

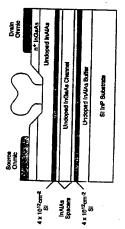
InyGa1-yAs on InP (y>0.53)

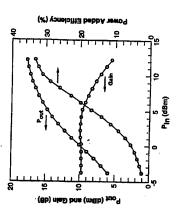
InxGa1-xAs on InP (x<0.53)

PSEUDOMORPHIC In. 48 Ga1,23 As/AlinAs TEGFET

Growth parameter

Power and efficiency characteristics

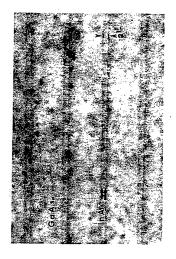




0.1 µm T-gate process, 200 µm gate width
Maximum frequency for oscillation fmax= 600 GHz, 58 mW at 94 GHz, F= 1.4 dB (Noise figure)
P.M. Smith IEEE EDL 5, 230 (1995)

InAs on GaAs

High Resolution Transmission Microscopy of a superlattice (InAs/GaAs heterostructure)



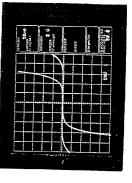
2D growth on very short scale to avoid the dislocation formation possibility to use such epilayers for potential perturbations



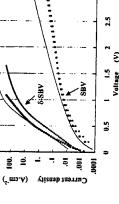
Heterostructure Barrier Varactor SINGLE AND DUAL

I - V curve at room temperature

Modeling of I - V curves



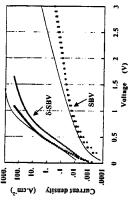
excellent symmetry Ø = 38 µm



Capacitance (IF/µm²)

J < 10A / cm² at 6 V

Département Hyperfréquences & Semiconducteurs



comparison between measured and calculated data

STRAINED AIAS BLOCKING LAYER

conduction profile

Epitaxy

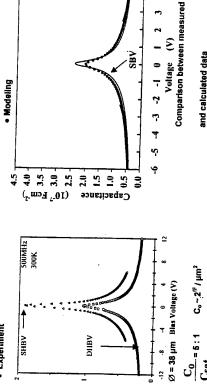
AlinAs / AIAs / AlinAs 600 blocking layer 200 300 400 500 Distance (nm) 3 accumulation layer 0.5 lsituato¶ S di 1-S di 0--1.5 1.0 0.0 -2.0 (V9) growth sequence nGaAs 1x10¹⁷ cm⁻³ nGaAs 5x10¹⁸ cm⁻¹ GaAs lx1017 cm. nGaAs 5x10¹⁸ cm⁻³ InP Substrate x2 for DHBV's

Département Hyperfréquences & Semiconducteurs

700

CAPACITANCE - VOLTAGE CHARACTERISTICS SHBV AND DHBV

Experiment



Co~2"/ µm²

Csat

and calculated data



DOUBLE BARRIER HETEROSTRUCTURE

(DBH's)

Fabrication techniques For high current structure L_b = 1.7nm $^\circ$

nGaAs	5x10" cm ⁻³	300nm
nGaAs	1x10" cm.3	50nm
nGaAs	Undoped	10m
IAs	Undoped	L.7nm
GaAs	Undoped	Snm
IAs	Undoped	Tom.
GaAs	Undoped	10m
GaAs	1x10" cm ⁻³	300nm
GaAs	5x0" cm-3	300nm
P Substrate	rate	

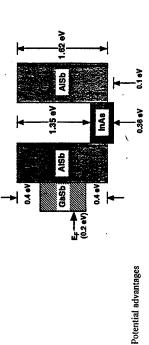
from RHEED intensity oscillations of alloy composition and growth rates Gas Source MBE equipment

- · InP (on InP)
- · GaAs and AIAs (on GaAs)

Growth sequence

ANTIMONIDE MATERIAL SYSTEM

Band structure lineups for GaSb/AISb/InAs:



High conduction band offset between InAs and AISb (RTD's and TEGFET's) low gap (high mobility, 33,000cm²/Vs) InAs material for high speed applications High peak and saturated velocity

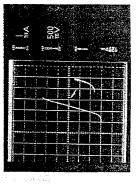
In counterpart:

Low breakdown voltage unfavorable for power applications no lattice matched SI substrate, immature technology

D - C CHARACTERISTICS

Typical current - voltage characteristics at room temperature (A ≈ 4μm²)





 $J_p = 175 \text{ kA} / \text{cm}^2$ $J_p / J_v = 5.5:1$ <u>e</u>

(b) Jp = 135 kA / Ccm2 Jp / Jv = 9:1

E. Lheurette et al Electonics letters 1995, 31, pp 1508 - 1509

Département Hyperfréquences & Semiconducteurs

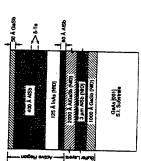
ANTIMONIDE TEGFET

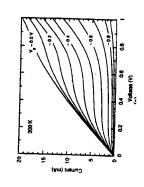
Motivations:

high carrier sheet carrier density High velocity including overshoot for ultra short gate length but low breakdown voltage

epitaxial material

Current-voltage characteristics





J. D. Werking et al. IEEE EDL, 13, 164(1992)

METAMORPHIC GROWTH

Sb-based material system grown on GaAs substrate (Resonant tunneling InAs/AISb RTD's) InAIAs/InGaAs on GaAs possibly Si in the future(high performance TEGFET's)

A buffer layer separates the substrate from the active layer so that the strain can be relaxed Relaxation of strain, blocking of dislocations

Example of buffer structure

7500Å 3000k \$000S inAIAs;UD InAIAs:UD InAlAs:SI 10-52%In 52%In graded

•TEM for In_{0.3} Ga_{0.7}As on GaAs with gradual transitions buffer In_{0.15}Ga_{0.85}As



J. R. Söderstrom et al. Appl. Phys. Lett. 58, 275(1991), E.R Brown IEEE EDL 41, 879(1992) P.Win et al., D.E. Grider et al. T. Mishima et al., N. C. Tien et al.

EPITAXIAL LIFT-OF TECHNIQUE

Basic idea:

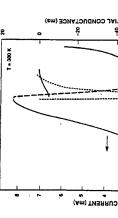
and subsequent bonding on another substrate by van der Waals forces E. Yablonovich Appl. Phys. Lett. 51, 2222(1987)

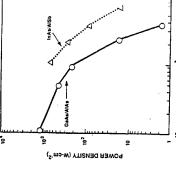
The epilayer can be processed before or after the bonding. This technique has to be distinguish from thinned wafers with bonding on low permittivity substrate

METAMORPHIC RESONANT TUNNELING DIODES

•Typical I-V Characteristics (Jp>300kA/cm²)

output power versus frequency





E. R. Brown et al. APL. 58, 2292(1991)

VOLTAGE (V)

5

0.5

FREQUENCY (GHz)

8

Remove the active layer from the substrate by means of selective etching

							•
n-GaAs n=4x10 cm.	1500Å emitter n-Ales GaAs n=5x10 cm	p=5x101sm,	n=5x 10 ¹⁶ cm ⁻³	8000Å subcollector GaAs n=4x10"tm3			strate
n-GaAs	r n-AlasGa	P-GaAs	tor GaAs	lector GaA	AIAs	n GaAs	GaAs substrate
2000Å cap	1500Å emitte	1000A base	5000Å collector GaAs	8000Å subco	Y 001	E L	*#

Service	į,	Carter Conc. car ²	M. 1087.2	q diag	Course Makely	(m)	
1		On-maker	OTE		On make	ora	
2	8	9.4 x 1011 R.7 x 1911	£7 ± 50 ¹¹	£9÷	386	100	ŝ
	•	L95 x 1011 6.2 x 1011	8.2 x 1011	-4.1	79300	63865	£61·
3	8	11.7 x 10.11 10.5 x 10.11	101 1 201	72	alt	396	9781*
4	•	199 1011	110116	7	\$£	7	-552

CONCLUSION

From the material point of view

•GaAs system: Mature technology, high performance Schottky's Nonstoichiometric material (LTG GaAs) with ultra fast decay of photoexcited carriers

Pronounced Negative Differential Resistance effect at room temperature for RTD's •InP-based materials: The frequency capability of InP-based material was demonstrated with ultra high cut-off frequency for pseudomorphic TEGFET AlmAs/InGaAs.

Antimonide material system

record oscillation frequency with InAs/AISb double barrier heterostructure High sheet carrier density, high velocity TEGFET's But immature technology, low breakdown voltage

From the structure point of view

Various heterostructures were tailored for improved performances

Single barrier varactors with AIAs blocking layers for varactor operation
Strained layer Double Barrier Heterostructure for high peak-to-valley ratio and High current density Superlattice with transit time limitations

Planar doped TEGFET's with high current drivability

I would like to thank O. Vanbésien for his help in this overview

Technical Issues of Terahertz Component Fabrication

þý

R J Wylde

Thomas Keating Ltd Billingshurst West Sussex HK

In remote sensing of the atmosphere - from space and from the ground - in the development of Tokomak fusion reactors for 21st Century energy production and in probing the heavens, Terahertz technology can contribute to some of the 'Grand Challenges' facing mankind at the end of the 20th Century.

This talk is about making things to deal with Terahertz radiation. And rather large things, on a terahertz reduced scale, rather than very small things (such as Schottky diodes). They will also be linear things, so they are not involved in the actual non-linear process of generating or detecting Terahertz radiation. It will not be a very exciting talk, in the context of others you will have and are about to hear at this conference. But it might be a useful one.

I will be talking about the manufacture, and before that, the design of a variety of Terahertz components. These will include

Beam forming and receiving components

Beam control components

Beam processing components

Beam absorbing components

Inevitably, most of these will be drawn from systems that I have been involved in, but I will try to cover as wide a range as possible.

Integrated Waveguides and Mixers

þ

C Mann

Rutherford Appleton Laboratory UK

(No material supplied.)



New directions in terahertz technology

Integrated active devices

D. Lippens

UMR CNISS 9929 Université des Sciences et Technologies de Lille 59632 Yilleneuve d'Ascq Cedex, France Institut d'Electronique et de Microélectronique du Nord

Chateau de Bonas, France July 11, 1996

EPITAXIAL GROWTH

Molecular beam epitaxy techniques

Solid Source MBE (SSMBE)

Growth of: •GaAs-based materials

Ak,Gat...As (0<x<1)

Typical growth temperature: 600°C for GaAs

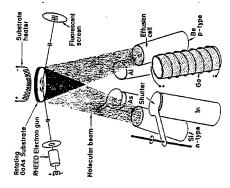
700°C for AlAs

Ino33Gao41As, Ino32Alo48As (T~530°C) InP is used as a substrate InP-based compounds

Gas Source MBE (GSMBE)

Growth of InP related compounds:

Binary and ternary Alloys In, Ga₁, As and In, Al₁, As Quaternary Galn AsP Type II Heterostructure (InP/InAlAs)





Outline

Epitaxial growth and ion implantation MBE and MOVPE techniques lon implantation

Basic technological process Ohmic contact

Schottky's contact

Wet etching Device isolation

Reactive Ion Etching (RIE) Integration techniques

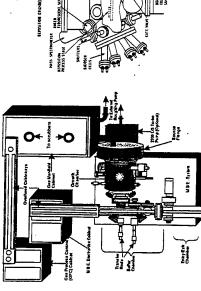
dielectric cross over and planarization Air-bridge interconnections

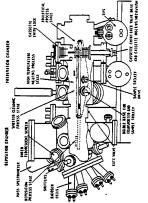
Schottky's diodes for mixer and harmonic multipliers High frequency devices

Heterostructure devices Low noise TEGFET's

MOLECULAR BEAM EPITAXY

Schematic view of a GSMBE or MOMBE growth apparatus

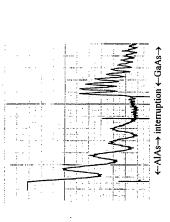




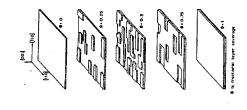
Several MBE systems can also be in series including surface analysis tools (ESCA and STM ...)

IN SITU ANALYSIS TECHNIQUE

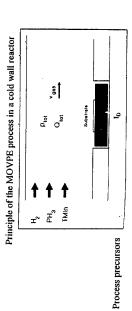
Reflection High Energy Electron Diffraction (RHEED)



Growth interruption for limiting the interface roughness



METAL ORGANIC VAPOR PHASE EPITAXY (MOVPE)

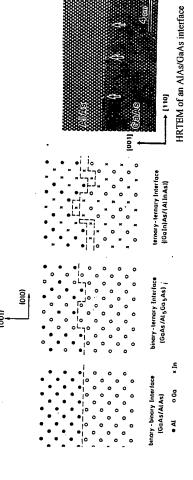


Element	Precursor	Formula	Vapor Pressure @ 17°C	Melting Point
Aluminum	Trimethyl Aluminum (TMAI)	Al(C,H,),	9.13 mbar dimeric	15.4°C
Gallium	Trimethyl Gallium (TMGa)	Ga(C,H,),	207.38 mbar monomeric	-15.8°C
Indium	Trimethyl Indium (TMIn)	In(C,H,),	1.76 mbar monomeric	88°C

Possibility to growth Phophorus-related compounds notably GalnP

INTERFACE ROUGHNESS

Characterisation by High Resolution Transmission Electron Microscopy (HRTEM) and more recently by Scanning Tunnelling Microscopy (STM)



Differences between the direct and indirect Hetero-interfaces

ION IMPLANTATION

Principle: dopants are introduced into the semiconductor by ion implantation Advantage: low cost and local doping

Process conditions

 Schematic of an ion implantation system ACCELERATION TUBE

First step: implantation

Typical energies: 30 to 400 kV

VARIABLE SLIT FOR BEAM CONTROL

small angle (6 to 10°) for avoiding channeling Doses 1012 to 1014 cm-2

WAFER (TARGET)

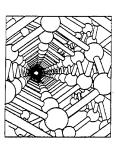
Second step: Annealing

in high temperature ovens or flash lamps ; $T\sim 800-900^{\circ}\mathrm{C}$

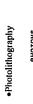
ION SOURCE

Illustration of ion channeling

•Main implanted species Silicon for n-type dopant Beryllium for p-type dopant



LITHOGRAPHY TECHNIQUES



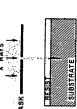
Electron Beam Lithography



ELECTRONS

·X-RAY Lithography

·lon beam lithography



Photolithography for patterning on the micron scale; e-beam and X ray for nanostructures

LITHOGRAPHY TECHNIQUES (II) (RESIST)

Positive Resists
 Spin coating

Negative resists spinning.



Revelation

Revelation

BASIC RESIST PROCESSES

Etch-process

resist spinning

Lift-off technique

Uniform metal deposition

undercut resist profile

metal etching

evaporation

resist removed

Lift-off

MULTILEVEL RESIST TECHNIQUE

 Tri-layer developed resist image 100nm T-gate

·Metallized gate formed by lift-off technique

•Multilayered resist technique TOP RESIST (FOR EXPOSURE)

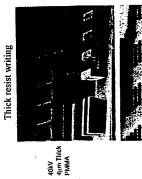
TRANSFER LAYER BOTTOM RESIST (ETCHED)

Photoresists or PMMA can be used

b) TAI-LEVEL

ELECTRON BEAM LITHOGRAPHY

E-beam writing of PMMA (Polymethylmethacrylate) Electron dose between 2x10⁻⁷ and 8x10⁻⁷ C/cm² development using MIBK (Methylisobutylketone)



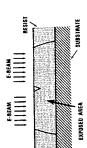
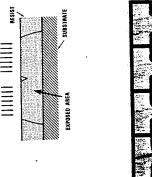


illustration of proximity effect



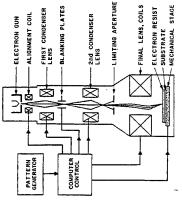
100kV 10µm Thick PMMA

SEM views showing the resist profiles versus electron dose

ELECTRON BEAM LITHOGRAPHY

Schematic of an electron beam machine

• Electron beam pattern generator (High resolution)



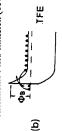
Electron energy between 20 and 100 kV Beam current less than 50 nA Spot size for high resolution ~10nm

OHMIC CONTACTS

Principle of conduction Thermionic emission (TE) (e)

Thermionic Field emission (TFE)

BERYLLIUM



Field emisssion

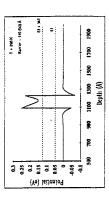
<u>ပ</u>

J_∼ Js exp (·q Φb/E00) with E00= qħ/2(Nd /ε m)^{1/2}

Special techniques for contact improvement Transition between large and low gap materials



Band bending for metal on n-InAs on graded n' In,Ga,,As/GaAs Planar doped epilayer



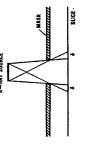
X-RAY DIFFRACTION

Principle: Soft X-rays (0.2-1 nm)

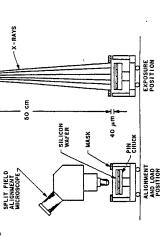
·Schematic of an X-ray lithographic system



Penumbra effect arising from non collimated rays



The optimum X-ray source is the synchrotron



OHMIC CONTACT (II)

Metal system used to form Ohmic contacts on III-V

•n-type GaAs

p-type GaAs

Ag-In	75% Ag, 25% In; sinter 500° C	Ag-In	25% in; alloy 500° C
Ag-In-Ge	90% Ag, 5% In, 5% Ge; alloy 600° C	Ag-In-Zn	80% Ag, 10% In, 10% Zn; alloy 600° C
Ag-Sn	98% Ag, 2% Sn; alloy 550-650° C	Ag-Zn	90% Ag, 10% Zn; alloy 450° C
	33% Ag, 67% Sn	Au-Be	1% Be
Au-Ge	12% Ge (alloy); alloy 450° C	Au-Zn	
	Au overlayer	In-Zn	(to semi-insulating GaAs)
Au-Ge-Ni	12% Ge (alloy), Ni; alloy 480° C		
Au-Ge•In			
Au-Si	alloy 425° C		
Au-Sn	20% Sn; alloy 450° C		
Au-SnNi-Au	alloy 300° C		
Au-Te	10% Te; laser alloy		
	2% Te; alloy 500° C		
	300° C melt		٠
In-Al	alloy 320° C		
In-Au	90% In; alloy 550° C	Non alloyed oh:	Non allowed obmic confect on highly down of
In-Ni	Ni plated to in	Total alroyed offi	incomact on inginy noped oc
Pd-Ge	sinter 500° C two hours	Deep oninic con	Deep oninic confact with subsequent annealing
Sn-Ni	Ni plated to Sn; alloyed		
Sn-Sb	4% Sb; alloy 300-350° C	Shallow ohmic contact :PdGe	contact :PdGe

WET ETCHING

Anisotropy considerations

Background

Etching operation for semiconductor:

·by oxidising the surface

by dissolving the oxide

by removing some of the SC atoms

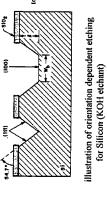
Basic limiting mechanisms

etch rate controlled by:

•the rate at which reactant species reach the surface (diffusion limited or mass-transport-limited etching) Diffusion coefficient ~10-9 m2/s

•the rate of chemical reactions (reaction-rate-limited or kinetically limited etching)

for GaAs (H2SO4 solution)





OHMIC CONTACT (III)

Characterisation techniques by Transmission Line Model (TLM)

•Basic pattern to measure the contact resistance

Plot of measured resistance versus contact separation



1-1-1

The resistance can be normalised to the contact area using the transfer length

Order of magnitude On GaAs (Nd=2x1018 cm⁻³) Rc< 2x10:6 Ω cm²

On In_{0.53}Ga_{0.47}As (Nd=5x 10^{18} cm-³) Rc < $2x10^{-7}$ cm² Rapid thermal annealing 430° C 30s

WET ETCHING

Principle: use of wet etchants to remove semiconductor, dielectric or metal

Etch of III-V semiconductor

NH4OH/H2O2/H2O H2SO4/H2O2/H2O GaAs:

HCI/H20 InP:

H3PO4/H2O2/H2O InGaAs

Platinium: HNO3/HCI/H2O (1:7:8)

Titanium: HF/H2O (1:9)

Gold: HCI/HN03 (3:1) KI/I2/H2O (4g:1g:40ml)

Etchants for Metals

Selective Semiconductor etchant

Basic mechanisms in wet chemical etching AlGaAs/GaAs: citric acid/H2O



SiO2: HF, BHF (Buffered HF)

Dielectrics

Si3N4: HF, BHF, H3PO4

Al2O3: HF, BHF, H3PO4

HF: Hydrofluoric acid

DRY-ETCHING

Main goal: achieve etch anisotropy

Plasma etching

The plasma generates reactive species They serve to chemically etch material More and less directionality Equipment: barrel As=A₀ Pressure 0.1-5 torr

•Reactive Ion Beam Etching(RIBE)

The wafers are separated by an acceleration grid ion energy > 1 KeV Kinetically-Assisted physical etch Similar to RIE except that

As= area of electrode holding wafers A0= area of other electrode KA: Kinetically assisted

Reactive Ion Etching (RIE)

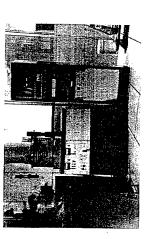
Planar equipment with A₀>As Low pressure 0.01-0.1 torr K-A chemical etching High directionality

fon milling

Use of ions of inert gas generated and collimated < 10 4 torr, Ion beam accelerator Pure mechanical process

DRY ETCHING

Physical etching equipment

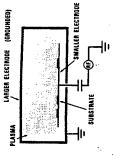


Reactive Ion Etching apparatus



REACTIVE ION ETCHING

Schematic of a reactive plasma equipment



Use for:

mesa isolation with vertical walls etching of via holes

InP-based material: CH4/H2 gas species: GaAs material : CCI, +O,

in an InP-based heterostructure Pressure 50m torr, power density 0.4W/cm² Bias voltage 340V Illustration of a mesa etched

DIELECTRIC DEPOSITION

Silicon Nitride (Si₃N₄) used most in GaAs processing

Deposition by Plasma enhanced Chemical vapor deposition

(PECVD)

Silane (SiH4) used for the Silicon source Nitrogen (N2) or Amonina (NH3) used for the nitrogen source

Overall reactions:

3SiH4 + 4NH3→ Si3N4 + 12H2

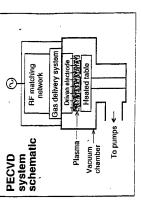
3SiH4 + 2N2→ Si3N4 +·6H2

Properties of SixNyHz

Dielectric constant: 6-9
Dielectric strength(V/cm): 6x106 Refractive index: 1.9-2.2

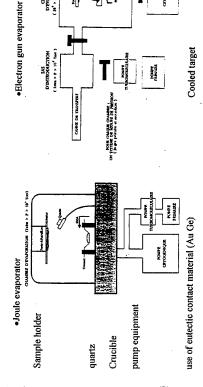
Bulk resistivity: $4-7\times106~\Omega$.cm plasma etch rate CF_4/Q_2 : 50~nm/min HF etch rate room temperature: 20-33~nm/min

Schematic of a PECVD system



for contacting planar integrated diodes Dielectric cross over

SCHOTTKY AND OHMIC CONTACT FORMATION



Sequential olunic contact with multi-crucible equipment

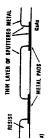
Possibility of Au/Ge sequential deposition good adhesion good electrical characteristics

BRIDGE INTERCONNECTIONS

SEM of an evaporated airbridge

Illustration of bridge formation

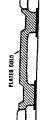
and metal deposition (sputtering or evaporation) spinning of a first resist



second resist coating

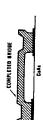


electroplating of gold





Completed bridge



ELECTROPLATING

Gold plating

Heating element

Process conditions

Control of pH Current density typically 5mA/cm² use of a gold cyanide complex Plating bath usually near 60 °C

temperature probe

a very thin layer of metal is applied to carry the current

Plating factor: plating area divided by total wafer area

Photoresist suitable for masking

Schematic of an electroplating system Reaction: Mn++ ne"=M° with M atoms of metals

plated sample

Platinium anode gold cyanide solution

•Use for Thick strip lines for coplanar transmission lines Free standing structures such as microswitchs Air bridge interconnections

AIR-BRIDGE INTERCONNECTIONS ON NANOMETER SCALE

Direct writing by Electron beam lithography

·variation of the electron dose

· favorable backscattering on the metal pads

Use of a P(MMA-MAA)/PMMA bilayer

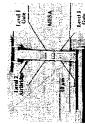
Illustration of a micro air bridge fabricated by direct writing



bi-layer developed resist image



use for fabricating electron waveguides



Starting from a high mobility 2D gas, electron waveguides can be formed assuming ballistic transport

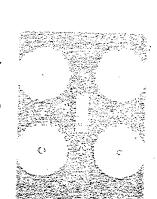


FABRICATION TECHNIQUES

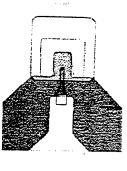
FOR WAFER PROBING

Simplified version

for directly contacting the samples



Planar Integration Techniques



air - bridged devices

three photolithography masks

Departement Hyperfrequences & Semiconducteurs

PLANAR INTEGRATION OF DIODES(I)

Surface channel diodes (Virginia University technology applied to InP-based material system)

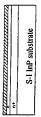
Schottky's epilayer n/n+/S-I InP substrate



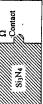


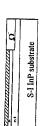
Deposit Silicon nitride film





Form Ohmic contact





IIII Recharge

PLANAR TECHNOLOGY

Low parasitic integration technique Air - bridged devices Lp(50pH) Rs (16Q)

-WW-_100000



Equivalent - circuit model
Parasitic capacitance 10fF
inductance 50 pH

electron - beam lithography

SEM of a 1 µm² diode

Departement Hyperfrequences & Semiconductours

Form anode

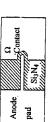
PLANAR INTEGRATION OF DIODES (II)





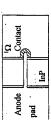


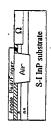
Form anode pad/finger



n S-I InP substrate

Etch surface channel

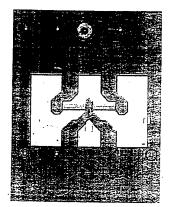




INP-BASED TEGFET (I)

Growth sequence of the epitaxial material

ChainAs: Si 4.10" 100 A AlinAs nid 200 A	AlluAs nid 10 A GalnAs nid 120 A	AllnAs aid 200 Å	Subsum inp st



Highly doped cap layer for Ω contact formation Undoped large gap InAJAs for Schottky contact formation Planat doping for high sheet carrier density in the 2 D gas buried AlinAs layer for better confinement

Growth by SSMBE or GSMBE

T-gate formation

Si3N4 deposition



Positive resist deposition e-beam patterning



TECHNOLOGICAL STEPS

Opening of the Si₃N₄ film CF4 plasma



deposition of a bilayer e-beam patterning

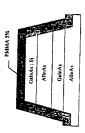


TECHNOLOGICAL STEPS

Ohmic contact formation

positive resist deposition

Ni/Ge/Au/Ni/Au deposition



AffinAs GalnAs AffinAs Lift-off and annealing



e beam patterning



BACKSIDE PROCESSING

Wafer thinning

Deep etch-back for membrane formation

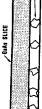
Electropiated gold

Wafer probing

motivations: use of a flip-chip technology thermal reason

lapping techniques

A slurry of water and grit is used between the wafer and a flat plate





CONCLUSION

High quality epilayer with multiple heterostructures can now be fabricated using molecular beam epitaxy

For operation at millimeter and submillimeter wavelengths the devices are now patterned on the micron and submicron scale notably by e-beam writing

Good Ohmic and Schottky's contacts (ideality factor ~1 , low contact resistance) are fabricated with a high

Dry and wet etching are often combined in planar integration of the devices

Development of whiskerless contact technology by dielectric cross over or air-bridged devices

Successful fabrication of high performance devices notably of

- TEGFET with T-gate
- Planar Schottky diodes
- Single barrier and double barrier heterostructures

I would like to thank P. Mounaix for his help in this overview

SCOPE

- INTRODUCTION
- POWER COMBINING ARRAYS
- GRID APPROACH
- ARRAY TYPE 2-DIMENSIONAL COMBINERS SINGLE ELEMENTS
- BEAM-CONTROL
- BEAM-SCANNING ARRAYS BEAM SWITCHING ARRAYS RETRODIRECTIVE ARRAYS OTHERS
- CONCLUSION



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ACTIVE ANTENNA POWER COMBINING, BEAM CONTROL AND 2-D COMBINING

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Professor Tatsuo Itoh

Department of Electrical Engineering University of California, Los Angeles Los Angeles, CA 90095, USA 405 Hilgard Avenue,



UNIVERSITY OF CALIFORNIA, LOS ANGELES

NTRODUCTION

- Active devices at millimeter-wave frequencies have limited power
- In millimeter-wave spectrum, two-terminal devices deliver more RF power but with poor DC-RF efficiency
- Current technology has shown good progress in three-terminal devices
- There is a need to combine the power of many devices
- Transmission lines at these frequencies are lossy, resulting in poor power-combining efficiency
- To solve these problems, ACTIVE ANTENNA is sought
- An ACTIVE ANTENNA is one which integrates each active device directly to an antenna



INTRODUCTION (CONT'D)

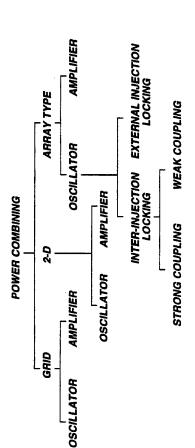
- Each element radiates its power through its own antenna
- This class of active antenna is the POWER-COMBINING ACTIVE ANTENNAS
- Another class of active antenna is the ACTIVE INTEGRATED ANTENNAS
- ACTIVE INTEGRATED ANTENNAS integrate as many RF functions as possible at the antenna front-end
- This allows compact integration, monolithic fabrication, and low RF lossesand system noise



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POWER COMBINING - GENERAL

Power combining active antennas can be further classified as follows:

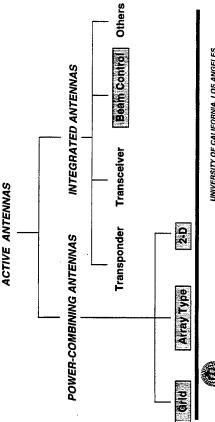




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INTRODUCTION (CONT'D)

ACTIVE ANTENNAS can be broadly categorized as follows:

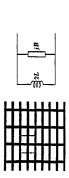




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POWER COMBINING - GRID APPROACH

- Grid approach does not adopt the conventional antenna array design consideration
- Grid concept exploits periodicity in the array that is small compared to wavelength
- The grid can be considered as an active sheet in free-space capable of amplifying signals or generating negative resistance





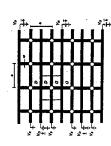
INDUCTIVE GRID

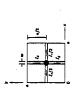
CAPACITIVE GRID



POWER COMBINING - GRID APPROACH (CONT'D)

- In an infinite grid, there is symmetry in the layout of the circuit. This allows electric and magnetic walls to be imposed when excited by a plane wave
- As such, analysis can be restricted to a waveguide cell in TEM mode
- Induced EMF is used to analyse the unit cell
- Leads of the active devices are treated as posts in a waveguide

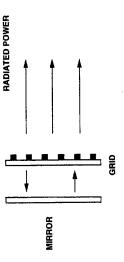




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POWER COMBINING - GRID APPROACH (CONT'D)

- Oscillator grid is designed to operate in a Fabry-Perot cavity
- A mirror is placed about one wavelength behind the grid
- The grid locks to the cavity mode with the lowest diffraction loss per round trip

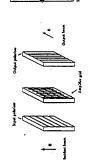




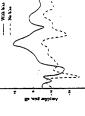
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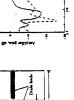
POWER COMBINING - GRID APPROACH (CONT'D)

- Currently, both amplifier and oscillator grids have been investigated
- In the amplifier grid, the unit cell consists of a differential pair FET or HBT
- Polarizers are placed on both sides of the grid as isolators
- Input and output signals have different polarization





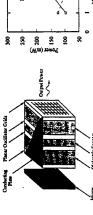


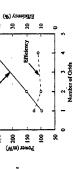




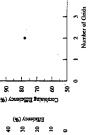
POWER COMBINING - GRID APPROACH (CONT'D)

- To increase the power generated, several grids are placed in parailel with dielectric spacers
- Interspacing between grids is experimentally determined
- Conducting plates are placed above and below to enforce TEM mode
- Four grids have been combined with 265 mW of delivered power





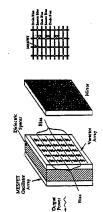


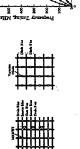


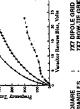


POWER COMBINING - GRID APPROACH (CONT'D)

- VCO grid incorporates a varactor grid behind the MESFET oscillator grid as the tuning element.
- Tuning bandwidth is about 10% with less than 2dB power change







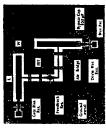
7X7 DIPOLE GRID 7X7 BOW-TIE GRID 4X6 BOW-TIE GRID

SQUARE TRIANGLES DIAMONDS

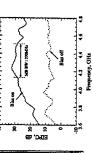
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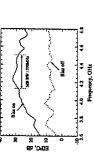
POWER COMBINING - ARRAY TYPE (CONT'D)

- In amplifier array, attempts have been made to broaden the bandwidth and incorporating more devices to an antenna
- To broaden the bandwidth, folded slot antennas have been used
- Folded slot antenna is relatively smaller and with wider bandwidth
- With CPW feed, the entire circuit is fabricated on a single layer









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POWER COMBINING - ARRAY TYPE

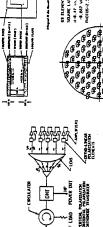
- The array is designed using conventional antenna array theory
- Both amplifier and oscillator arrays have been investigated
- In amplifier array, an antenna each is connected to the input and output of the amplifier element
- Input and output antennas are of different polarization to reduce mutual coupling and prevent feedback for oscillation
- In oscillator, emphasis in active antenna is on how to ensure in-phase synchronisation of the individual elements

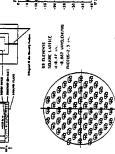


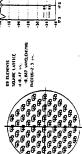
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POWER COMBINING - ARRAY TYPE (CONT'D)

- Another attempt to broaden the bandwidth uses stacked patch
- Orthogonal modes in the stacked patch is used to isolate the input from the output





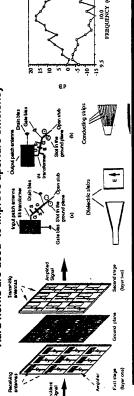


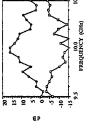




POWER COMBINING - ARRAY TYPE (CONT'D)

- To further isolate the input and output, patch antenna can be used
- The ground plane between the layers acts as a natural isolator
- The array is placed in the reactive field of the transmitting and receiving horns
- Hard horns are used to improve aperture efficiency



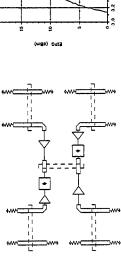


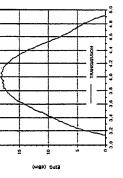


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POWER COMBINING - ARRAY TYPE (CONT'D)

- To increase bandwidth and allow integration of many active devices, slot antenna is used
- Slot antenna has a wider bandwidth than patch antenna
- Power-combining circuit does not occupy space as natural microstrip-to-slotline transliton is used.

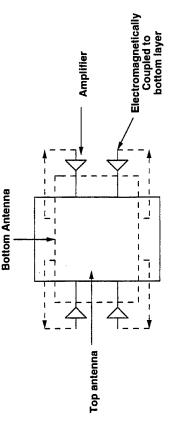




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POWER COMBINING - ARRAY TYPE (CONT'D)

To increase the power delivered by the array, more active devices can be incorporated into a single antenna





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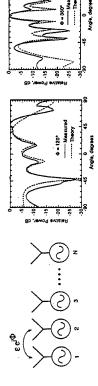
POWER COMBINING - ARRAY TYPE (CONT'D)

- As mentioned before, emphasis in oscillator arrays is how to synchronize the phase of each individual element
- Stephan has proposed INTER-INJECTION LOCKING
- Elements are mutually coupled (weakly or strongly)
- The system is then solved using differential equations of the amplitude and phase dynamics
- Weak coupling includes that of free-space between neighboring elements or lossy transmission lines
- Strong coupling includes direct connection of transmission lines or dielectric resonator coupling



POWER COMBINING - ARRAY TYPE (CONT'D)

- Here, the coupling network is the free-space coupling between elements
- Only coupling between adjacent elements is considered
- For a particular coupling phase, the interaction of the elements will result in broadside radiation

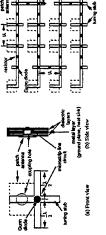


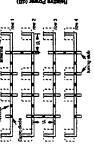


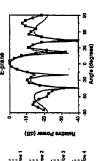
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POWER COMBINING - ARRAY TYPE (CONT'D)

- To account for strongly coupled oscillators, mode analysis is used
- Using AVERAGE POTENTIAL THEORY, the dominant and stable mode that provides in-phase oscillation is found





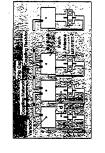


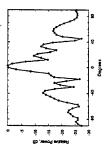


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POWER COMBINING - ARRAY TYPE (CONT'D)

- The analysis of strongly coupled oscillator is very involved
- To simplify the analysis, broadband coupling is assumed
- This is equivalent to a lossy transmission line





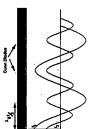


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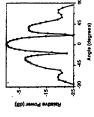
POWER COMBINING - ARRAY TYPE (CONT'D)

- By settling the interspacing to be half-wavelength at fundamental frequency, the second harmonic can be conditioned to radiate effectively
- Radiation of the fundamental signal is kept minimal as the phase relationship as a cancellation effect





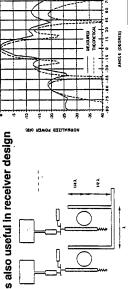






POWER COMBINING - ARRAY TYPE (CONT'D)

- To improve the phase noise of the array, injection locking is used
- Here, dielectric resonator is used as the coupling element
- The resonator is frequency-selective, thus there is no need to stabilize the dominant mode
- Phase noise of system is improved as the resonator is used
- This approach is also useful in receiver design

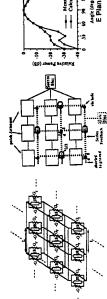


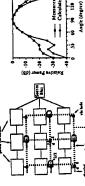


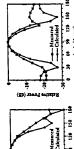
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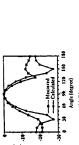
POWER COMBINING - ARRAY TYPE (CONT'D)

- Here, the system is treated as an entire system with one resonator This approach is the EXTENDED RESONANCE
- To achieve synchronization, the inter-connecting transmission line must be able to transform the reactance at one node to another node for cancellation of the reactance
- Then, oscillation will build up at the desired frequency







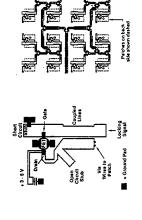


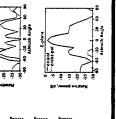


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POWER COMBINING - ARRAY TYPE (CONT'D)

- To synchronise the oscillation, injection locking can be used
- injected signal is divided in several stages to inject-lock the elements
- Through Kurokawa's analysis, the elements will be locked in-phase if the free-running frequencies of all elements are the same



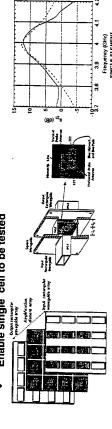




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POWER COMBINING - SINGLE ELEMENTS

- Although emphasis is placed on arrays, it must be noted that research in single element can lead to array implementation
- Also, quasi-optical array can be implemented using waveguides
- Short section of waveguide serves as isolator between cells and heat sinking structures.
- Enable single cell to be tested





POWER COMBINING - 2-DIMENSIONAL COMBINING

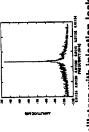
- Two-dimensional arrays are now arousing research interests
- Suggested by J. W. Mink et al, hybrid dielectric slab beam waveguide can be used for transmission of signals
- 2-D arrays allow monolithic fabrication
- 2-D is not restricted by the real-estate and DC bias circuitry can be easily incorporated
- Lenses are planar, and alignment of array and lenses does not require mounting structures
- Heat-sinking and support can be provided by the slab waveguide
- Measurement is easy as it behaves like a connectorized component



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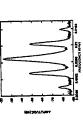
POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)





4 oscillators with injection-locking





With 350 KHz FM modulation

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POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

- Here, an oscillator combiner was designed
- Coupling between oscillators is achieved using the curved reflector
- Oscillator is designed not to excite surface-of-slab to ground-plane
- Vivaldi antenna is used to decouple the forward and backward waves
- TE modes, ie E field parallel to ground plane, are excited
- Through experiment, the placement of the oscillators is determined to ensure repeatable oscillation at the desired frequency



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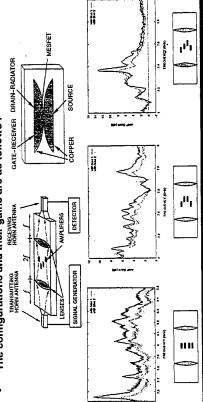
POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

- Similarly, an amplifier combiner was designed
- Several configurations of the amplifier placement were investigated
- Amplifier gain is the ratio of output power with and without bias
- Two groups of blas are measured
- Field strength is function of frequency and postion, hence different configuration has different power gain
- Placement of amplifier is experimentally determined to prevent oscillation and provide highest gain
- Since the amplifiers are not placed symmetrically, the amplification gain is not symmetrical



POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

The configurations and their gains are as follows:

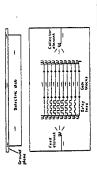




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POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

- Although low loss, the TE mode is difficult to excite cleanly
- Here, Yagi-Uda is used to excite the dominant mode with E field normal to the slab ground plane
- Microstrip delay lines are used to focus the guided waves
- Thickness of slab is chosen as such that center frequency is 90% of cut-off frequency of the 2nd order TM mode, thus maximizing coupling into DSWB

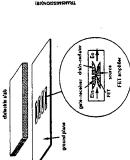


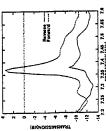


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POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

To reduce beammode perturbation, scattering losses and reflection of the amplifier, amplifier cells are located on the ground plane







System gain

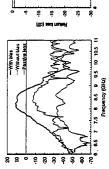


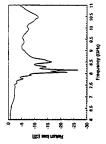
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POWER COMBINING - 2-DIMENSIONAL COMBINING (CONT'D)

Measured results of the 10-element combiner are as follows:

(Db) rinkg welligen A 8 5 6 6 8 8 8 8 8 8 7 7 8 8 8 8 8								
6.7 dB	-3.5 dB				-1.6 dB	1.6 dB		
Total measured loss (minimum)	Yagi-Uda slot array antenna losses (measured)	Input return loss = 10 dB Mismatch loss = 0.46 dB	Front-to-back ratio = 10 dB Back lobe loss = 0.41 dB	Total antenna element loss $4(0.46 + 0.41) = 3.5 dB$	Microstrip line losses (0.2 dB/in) (measured)	Deduced losses (spillover, radiation, and mutual		

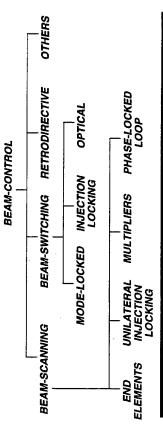






BEAM-CONTROL - INTRODUCTION

- To allow monolithic integration, phase control in active antenna must be achieved electronically
- Thus, ferrite-based phase shifter is not favored at all
- Various beam-controlled arrays are as follows:

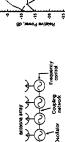




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BEAM-CONTROL - BEAM SCANNING (CONT'D)

- Through coupled-oscillator theory, there is a phase progression in the array when the end elements are detuned in frequency
- The amount of phase shift is proportional to the amount of frequency detuning
- The array still operates at a single frequency with over 180^o
 of phase tuning

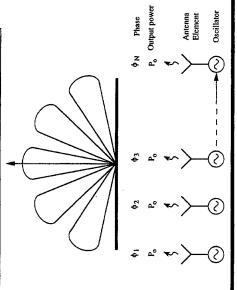






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BEAM-CONTROL - BEAM SCANNING

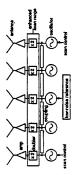




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BEAM-CONTROL - BEAM SCANNING (CONT'D)

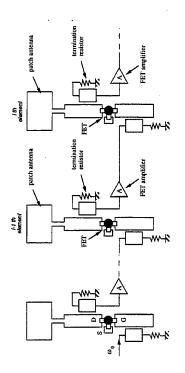
- To extend the previous concept, a multiplier is connected at each output of the oscillator before the antenna
- Intuitively, a 2X multiplier will double the phase difference in the oscillator
- This increases the scan range





BEAM-CONTROL - BEAM-SCANNING (CONT'D)

UNILATERAL INJECTION LOCKING

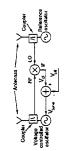




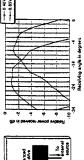
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BEAM-CONTROL - BEAM-SCANNING (CONT'D)

- Another form of phase control is to use phase-locked loop
- When within locking range, there is a phase difference between the locking and oscillating signals
- It is this phase difference that is used for beam-scanning





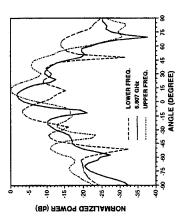




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BEAM-CONTROL - BEAM-SCANNING (CONT'D)

UNILATERAL INJECTION LOCKING





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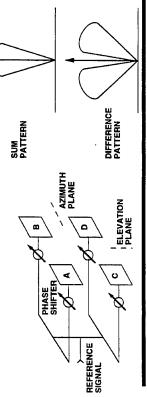
BEAM-CONTROL - BEAM-SCANNING (CONT'D)

- Grid approach has also demonstrated its capability in beam-scanning
- Diode grid has been implemented as phase shifter
- Fixed beam diffraction of 30^o has been reported by replacing the diode in the grid with gaps of varying sizes



BEAM-CONTROL - BEAM-SWITCHING

- Beam switching is used in radar application to extract target information, e.g. range and direction
- Conventional design uses bulky phase shifters to handle the high power transmission

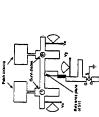


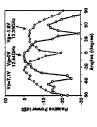


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BEAM-CONTROL - BEAM-SWITCHING (CONT'D)

- To furhter extend this concept with electronic tuning, an active device is connected between elements to switch between low or high impedances
- A FET is used here. The impedances are controlled by the V_{gs}



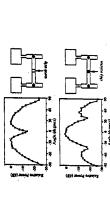


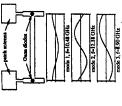


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BEAM-CONTROL - BEAM-SWITCHING (CONT'D)

- By using different modes in the strongly-coupled oscillators, different patterns can be generated
- When a resistor is connected between two elements using transmission lines, the stable mode is the in-phase mode
- When the elements are connected with through transmission lines, the stable mode is the out-of-phase mode

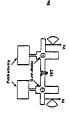




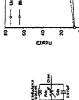
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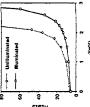
BEAM-CONTROL - BEAM-SWITCHING (CONT'D)

- To increase the degree of freedom for tuning, optical interaction is used
- Here, the photovoltaic and photoconductive effects are exploited
- By optical illumination, the FET characteristics are controlled to derive the necessary impedances





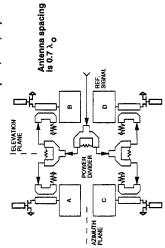






BEAM-CONTROL - BEAM-SWITCHING (CONT'D)

- Injection locking is used here
- Phase control is discretized (90°,-90°,0°)

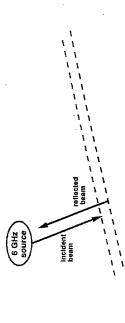




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BEAM-CONTROL - RETRODIRECTIVE ARRAY

- Incident beams are reflected back to the source without prior knowledge of the source location
- Retrodirectivity is not destroyed by conformally mounting or partially blocking the array
- Use in communications/RFID transponder applications

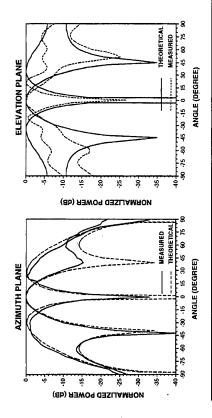




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BEAM-CONTROL - BEAM-SWITCHING (CONT'D)

Unilateral injection-locking array

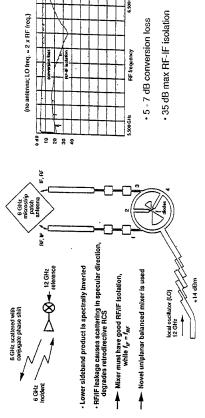




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BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

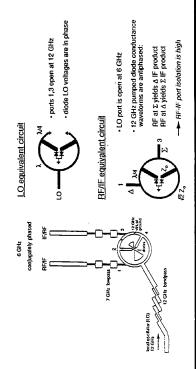
Phase conjugation via the heterodyne method





BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

Equivalent circuit





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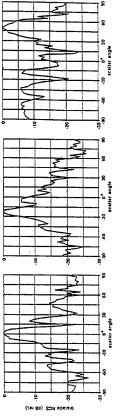
BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

Measured Bistatic RCS of the linear array

source at 0°

source at -20°

source at +45°



LO: 12.460 GHz, +20 dBm total RF incident: 6.215 GHz IF scattered: 6.245 GHz

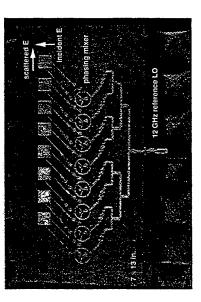
cross-polarized response



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BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

A 8X1 linear array

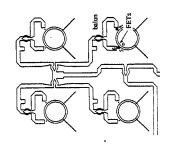


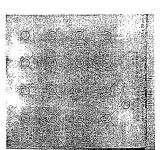


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BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

A 4X4 planar array with reference element

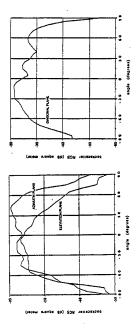






BEAM-CONTROL - RETRODIRECTIVE ARRAY (CONT'D)

Measured RCS of planar array





UNIVERSITY OF CALIFORNIA, LOS ANGELES

CONCLUSION

- A review of power-combining, beam control and 2-dimensional power combining arrays have been made
- It must be noted that single element, when properly considered, can lead to arrays
- There is a need to merge rigorous electromagnetic simulation with nonlinear analysis for active antenna
- This will account for all forms of coupling between elements
- Nonlinear analysis can then predict the amplitude and phase dynamics needed in active phased arrays



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BEAM-CONTROL - OTHERS

- It is worth mentioning that another form of beam-control is the polarization-agile active antennas
- Currently, reported works are single element
- By turning 'on' the appropriate active devices in an antenna, linearly and circularly polarized beams can be synthesized



GRID AMPLIFIERS

David Rutledge, Caltech

Ph.D. thesis of Jeff Liu (Rockwell)

Prepared for NATO ASI, Chateau de Bonas, July 1–11, 1996

-Caltech

Monolithic Grid Amplifiers

Gain Model Stability Model Hybrid HBT Grid Amplifiers

Monolithic HBT Grid Amplifier

Approaches to High-Power Millimeter-wave Amplifiers

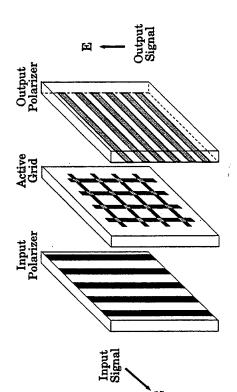
?altech-

Gain and Stability Model for HBT Grid Amplifiers

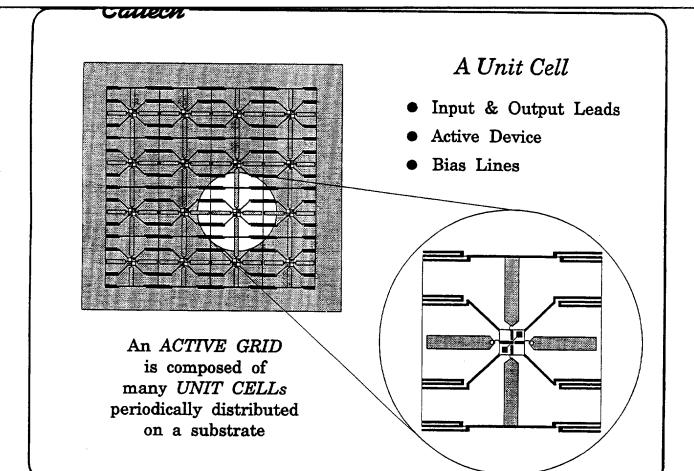
- ☐ Introduction to Grid Amplifiers
- Gain Model
- ☐ Construction and Measurements
- Stability Model

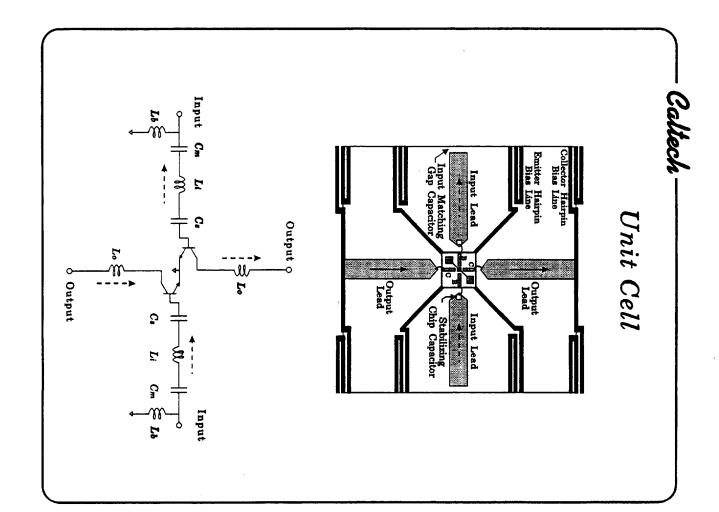
- Caltech

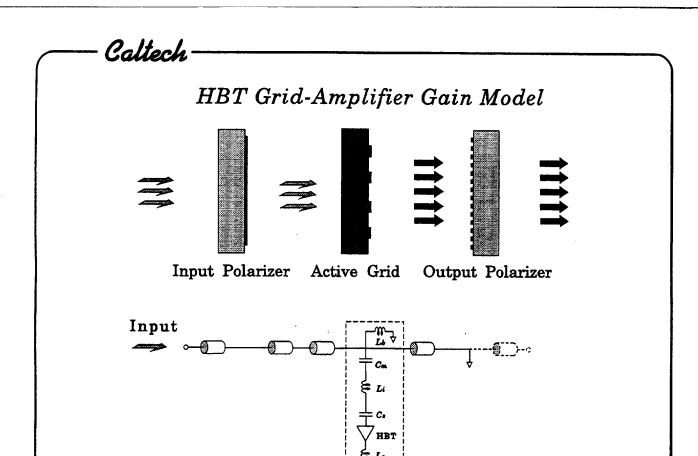
A Grid Amplifier



- Quasi-Optical Amplifier(Spatial Power-Combinig Amplifier)
- No conduction loss associated with the feed networks
- □ Power Capability
- Power proportional to the number of the unit cells
- Produce a high-power beam using many low-power transistors

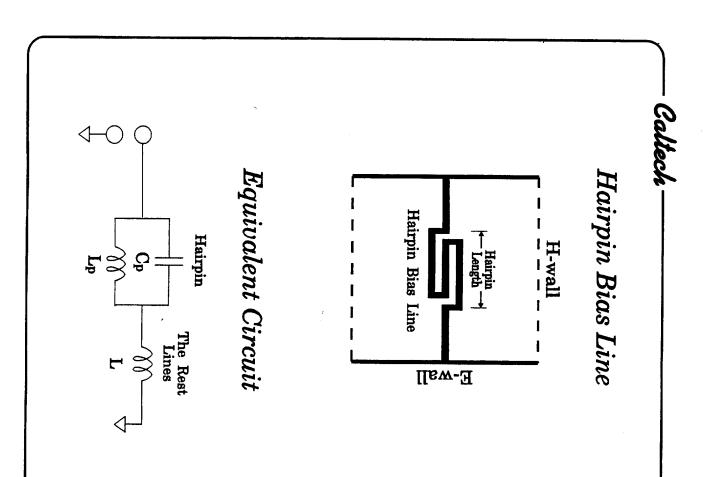


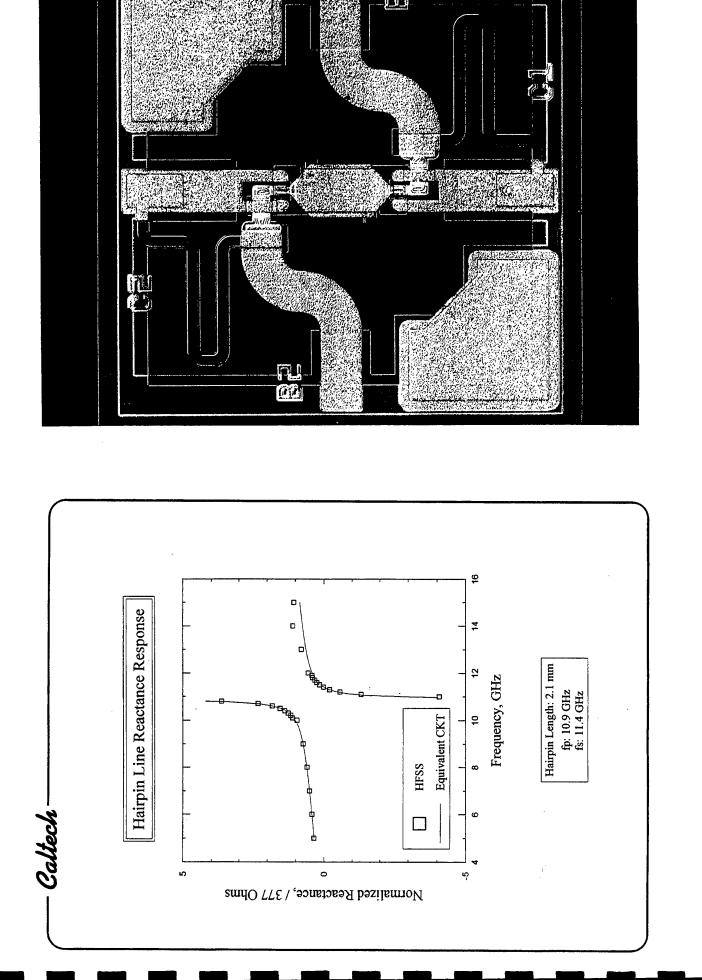




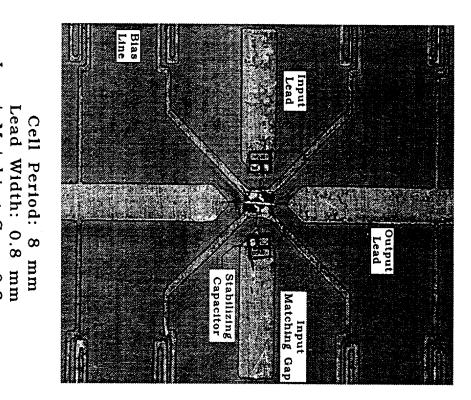
Half Cell

Output





10-GHz Hybrid HBT Grid Amplifier Unit Cell

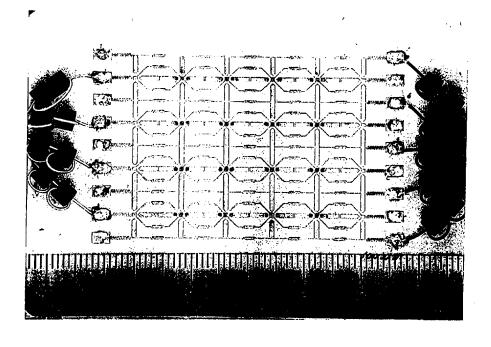


Caltech

Input Matching Gap: 0.2

mm

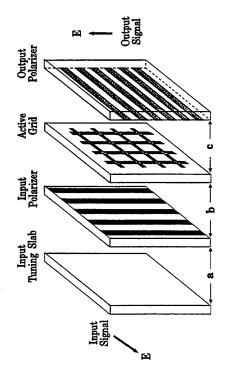
10-GHz HBT Grid Amplifier



Gmax: 11dB , BW: 350 MHz (3.5%)

Caltech

Assembled 10-GHz Grid Amplifier

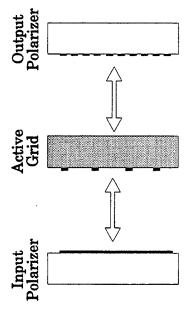


Tuning Procedure:

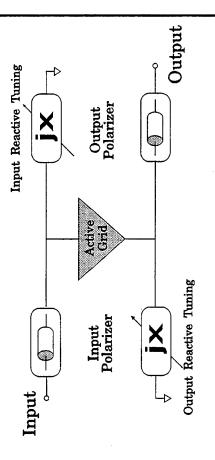
☐ Changing air spacings: a, b , and c ☐ Optimize the gain at 10-GHz

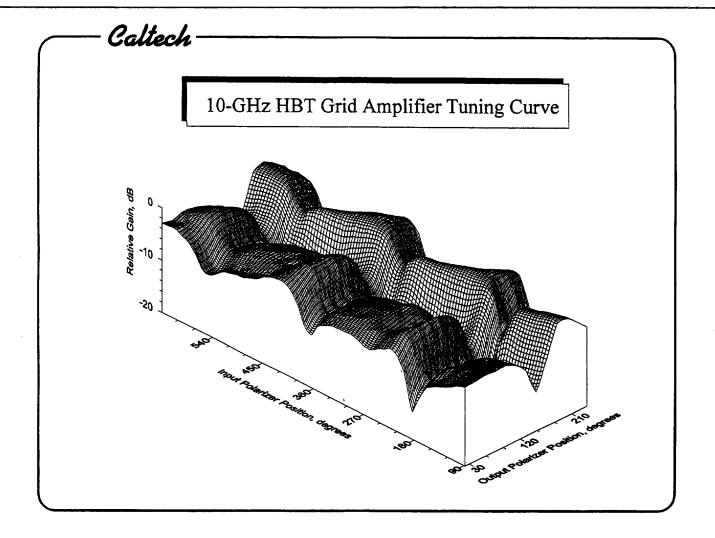
- Caltech-

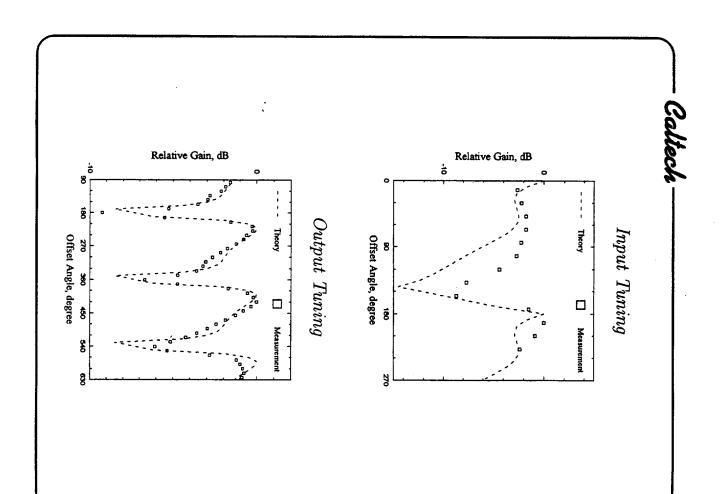
Tuning Grid Amplifier



Equivalent Circuit







Measurement 10-GHz Hybrid HBT Grid Amplifier with 0.18-pF Stabilizing Capacitors Gain: 11 dB @ 9.9 GHz BW: 350 MHz (3.5%) Frequency, GHz Theory -10 10 0 Gain, dB

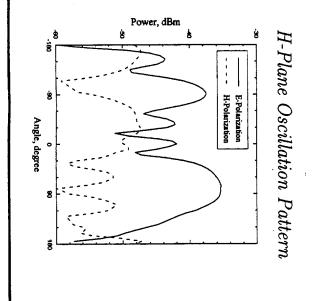
Common-Mode Oscillation

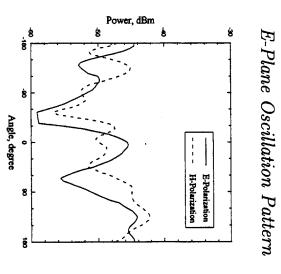
Oscillating at 7.8 GHz @ 2mA/transistor

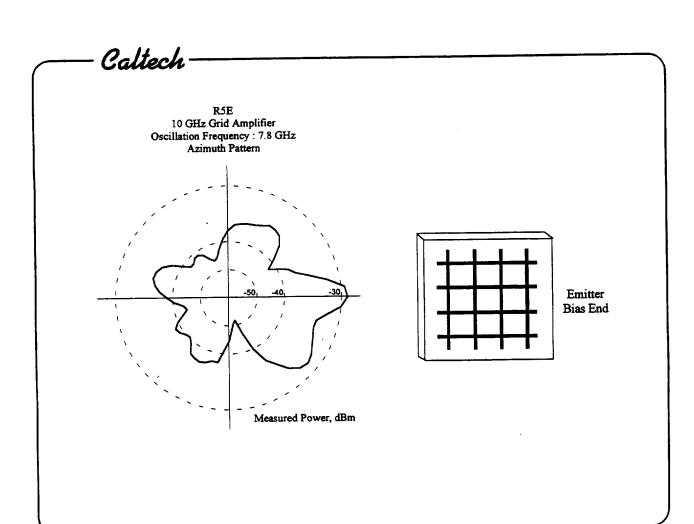
Sensitive to the unit cell

Not sensitive to the polarizer positions

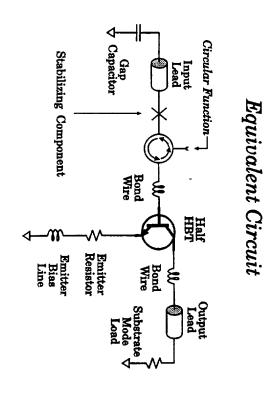
The greatest power density is in the plane of the grid

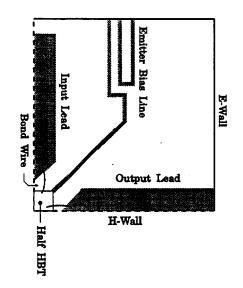






Quarter Cell



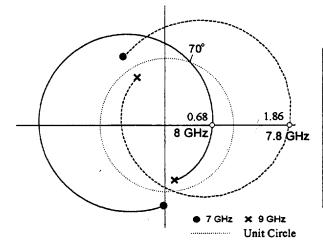


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Stability Analysis

a Stabilizing Capacitors

Circular Function



Without Stabilizing Capacitor

Unstable,

Potentially Oscillating @ 7.8 GHz

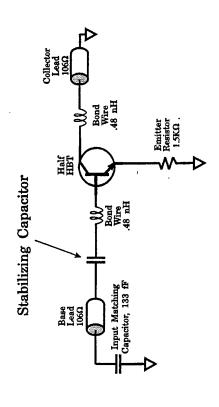
- With Stabilizing Capacitor, 0.1 pF

Stable with

Gain margin: 3.4 dB Phase margin: 70 degrees

Saltech

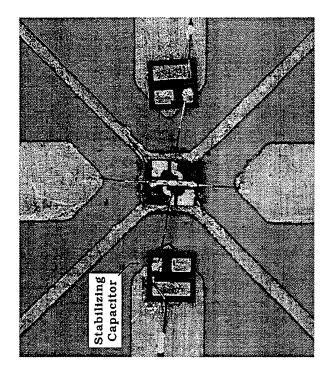
Stabilizing the Grid Amplifier



Positive Phase Shift of Circular Function

Caltech

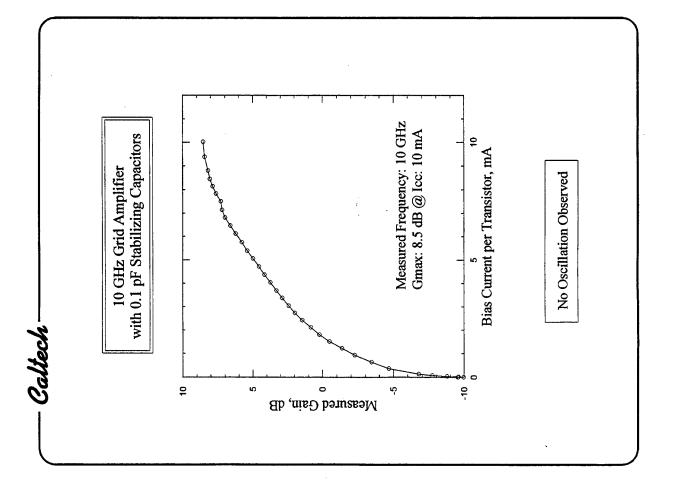
Closeup of Unit-Cell Center



Smaller Capacitance

믁

Higher Stability



-Caltech-

Summary of Hybrid HBT Grid Amplifiers

Gain Model and Comparison of Theory and Measurement

Stability Model

Common-Mode Oscillation

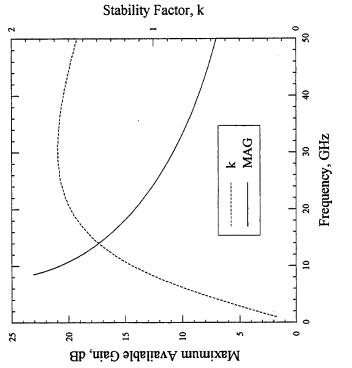
Stable Grid Amplifier



40-GHz Monolithic HBT Grid Amplifier Bias Current: 16 mA/transistor

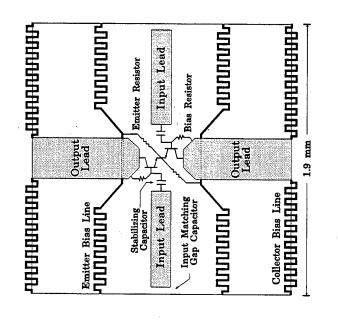
Gmax: 5 dB @ 40 GHz Pmax: 670 mW @ 40 GHz

Rockwell HBT Transistor 12 20 Maximum Available Gain, dB Monolithic HBT Grid Amplifier Cheh-Ming Jeff Liu, David Rutledge and Radiation Patterns Emilio Sovero, Wu Jing Ho Aiden Higgins Unit Cell and Models Power Measurements Gain Measurements Rockwell Science Center Michael DeLisio Tuning Curves CaltechTiling



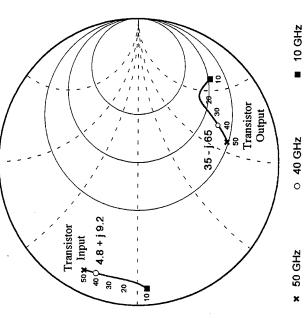
@ 40 GHz MAG: 9 dB; k: 1.6

40-GHz Monolithic Grid-Amplifier Unit Cell



Input-Matching-Cap. Gap: 30 um Output-Lead Width: 296 um Input-Lead Width: 120 um Unit-Cell Period: 1.9 mm

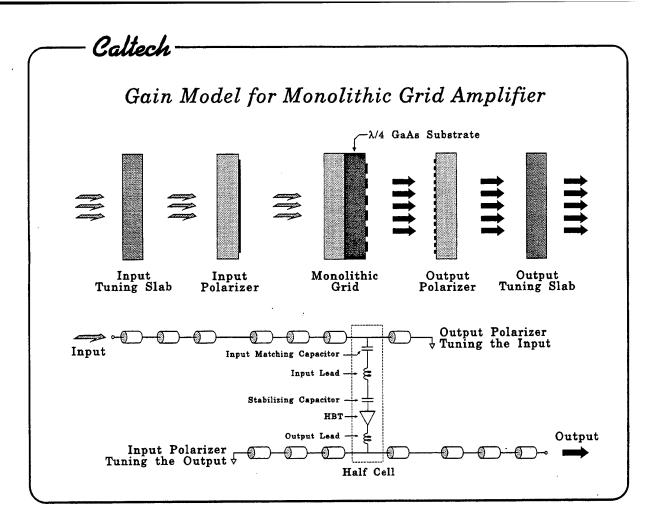
Optimal Transistor Impedance Rockwell HBT Transistor

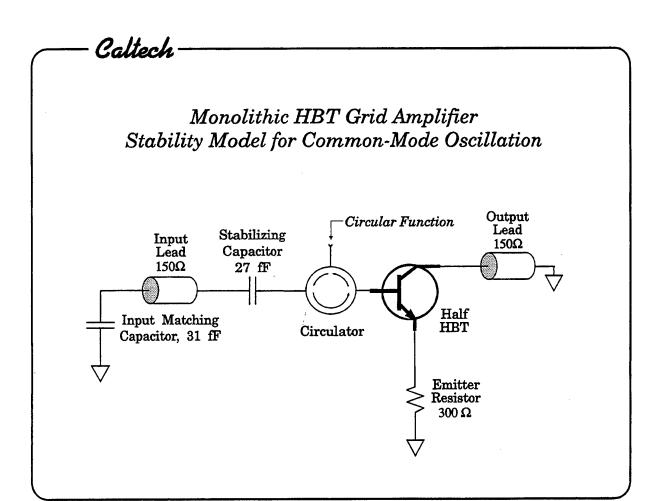


× 50 GHz

o 40 GHz

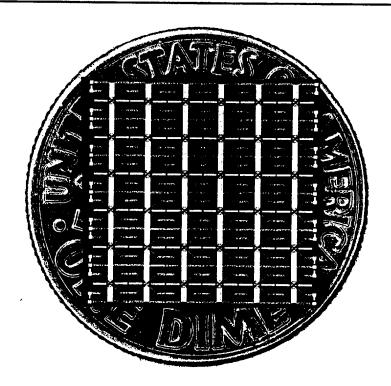
@40 GHz, MAG: 9 dB





Monolithic Grid Amplifier

SCP.0816A.041395



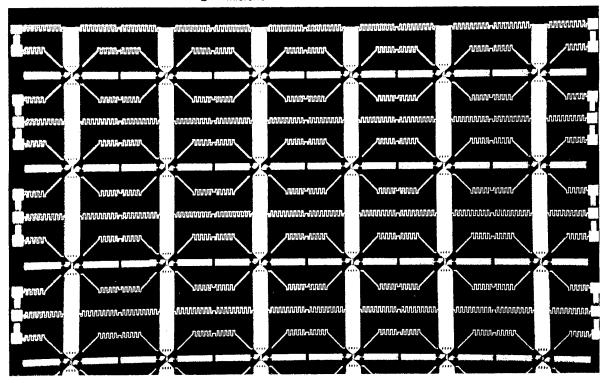


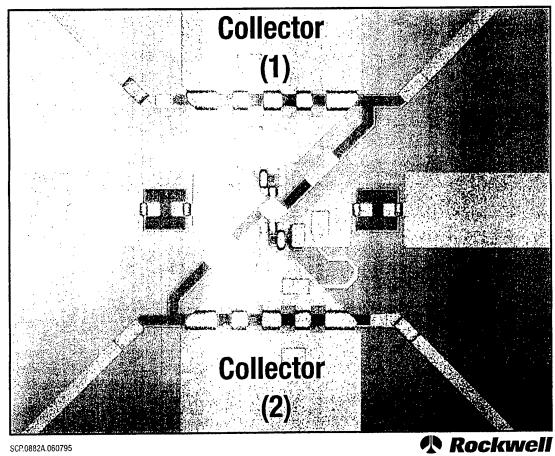


turd and material material and

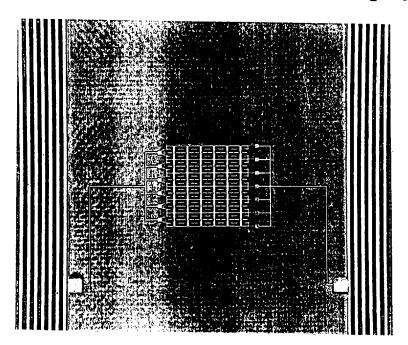
0 500 1000 1500 2000 2500 3000 3500 4000



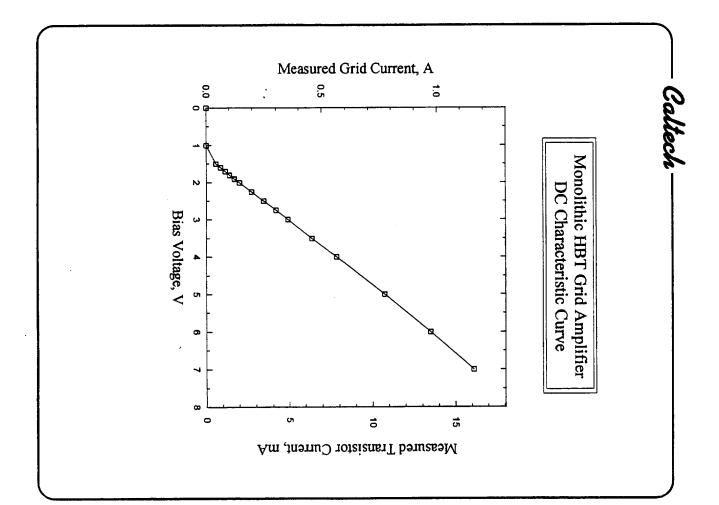


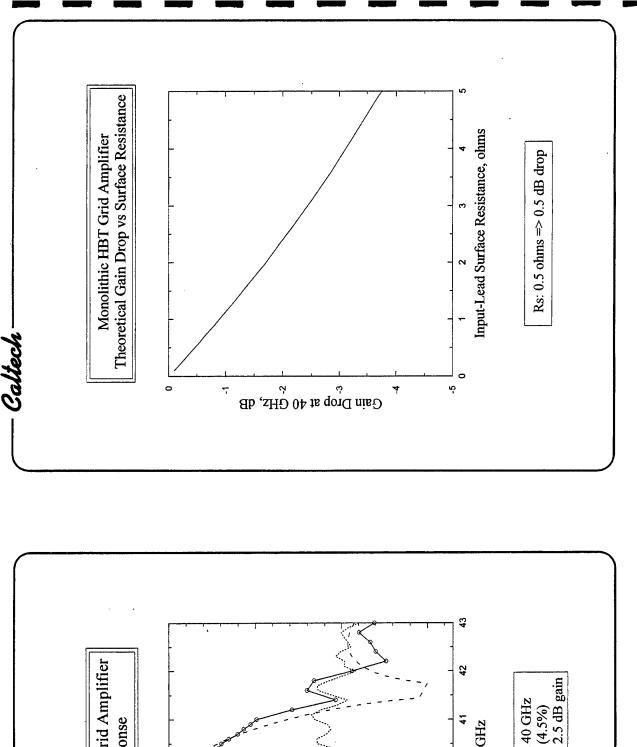


Callech
40-GHz Monolithic HBT Grid Amplifier



Gmax: 5dB, BW: 1.8 GHz (4.5%)





Monolithic HBT Grid Amplifier

Gain Response

Measuwed Gain Response

Measuwed Gain Response

Measuwed Gain Response

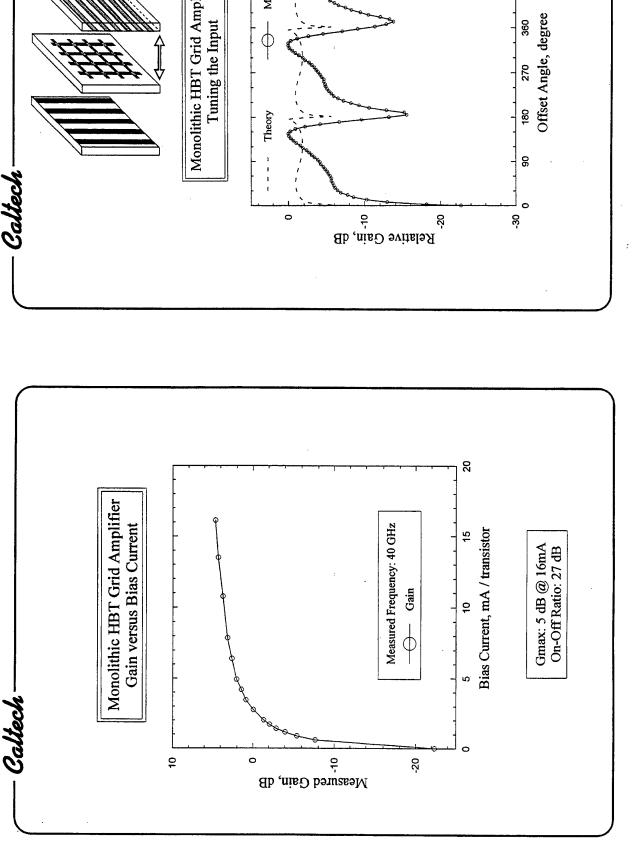
John Measuwed Gain Response

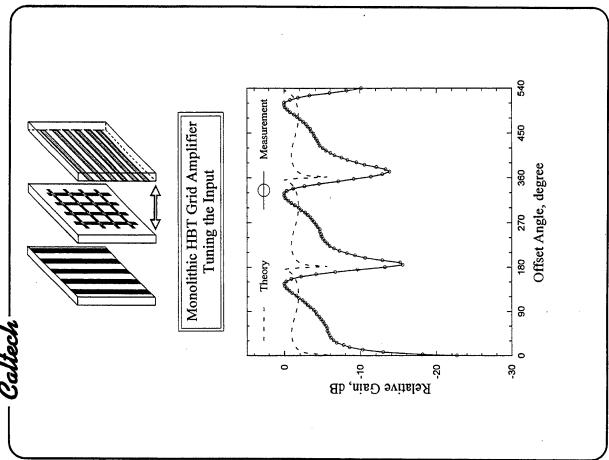
Say 38 39 40 41 42 43

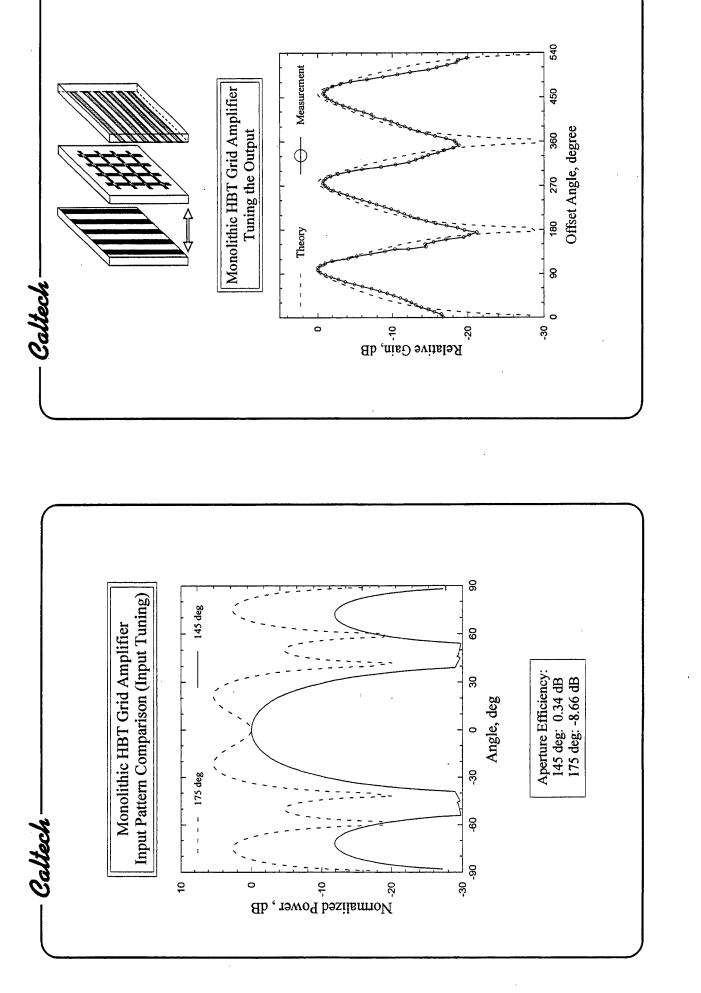
Frequency, GHz

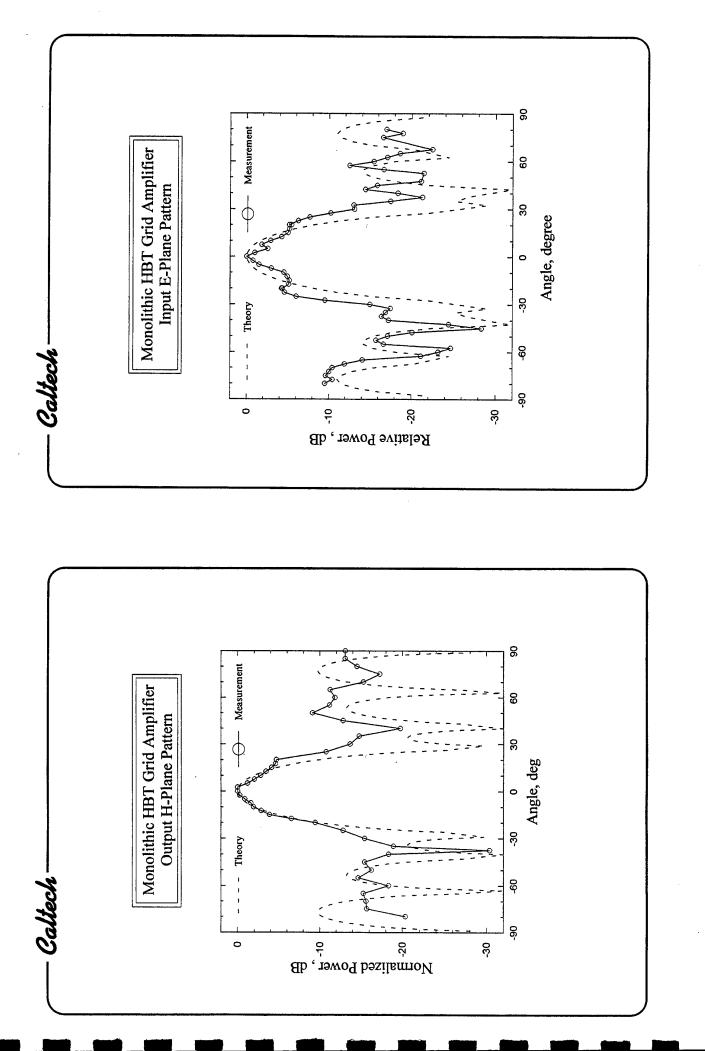
BW: 1.8 GHz (4.5%)

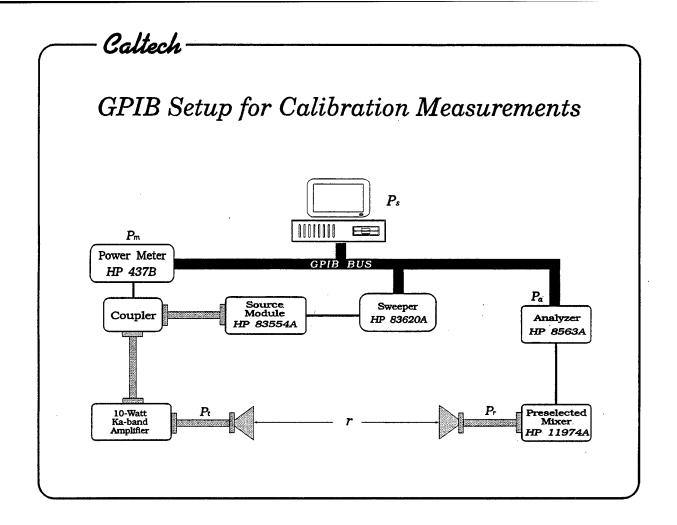
Pmax: 670 mW @ 2.5 dB gain

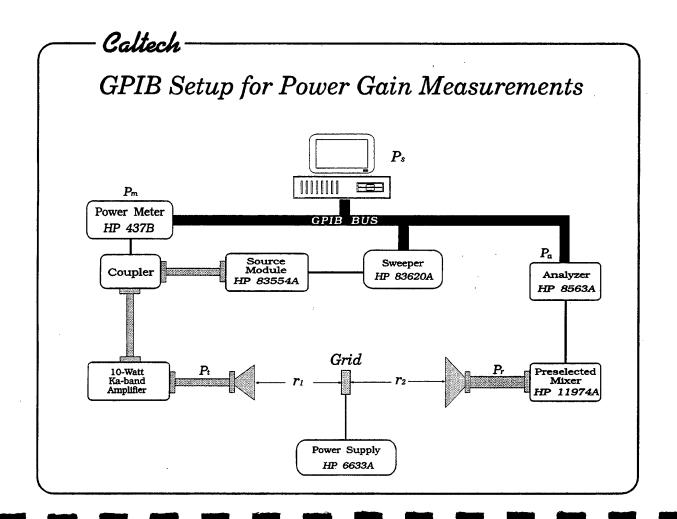


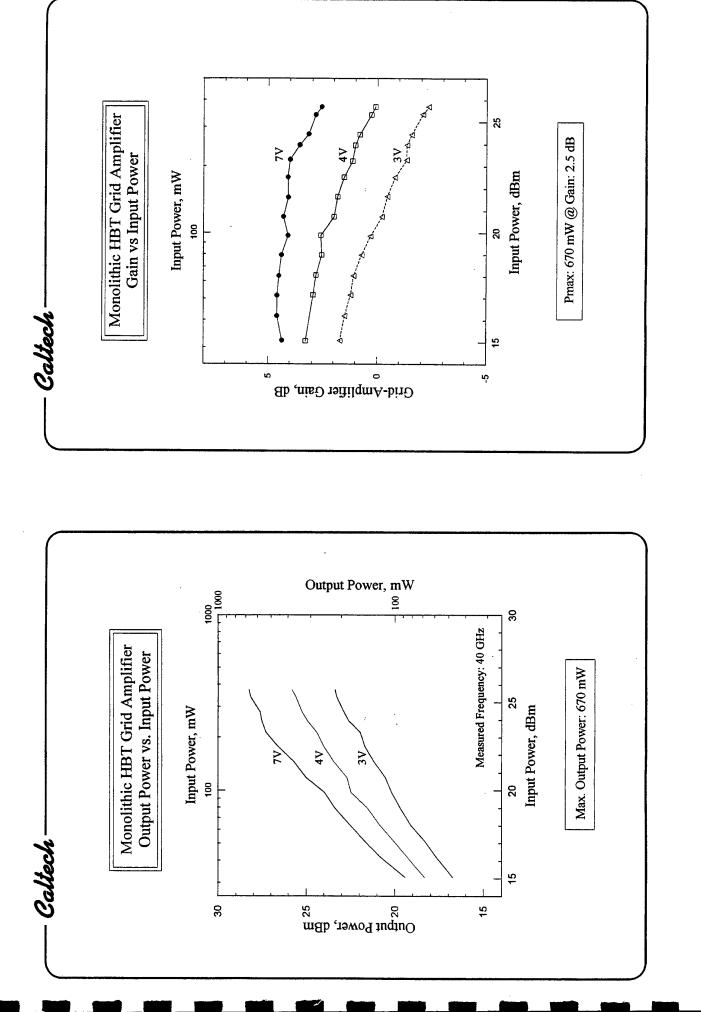


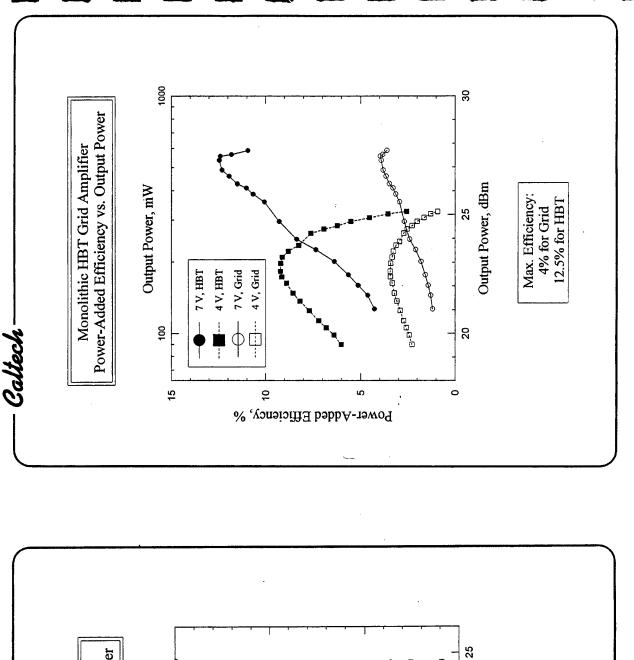


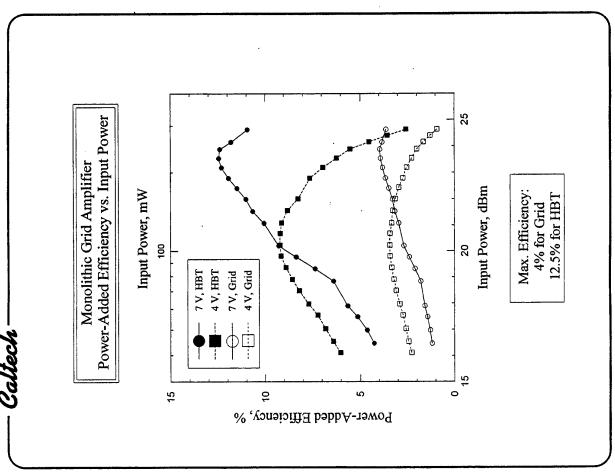


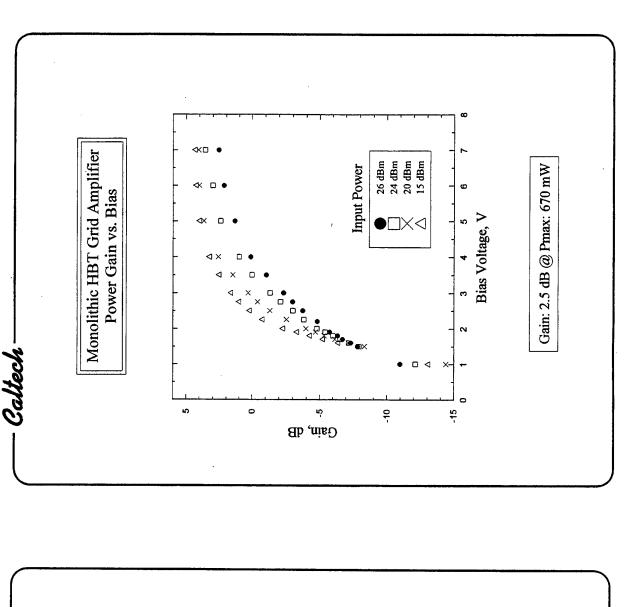


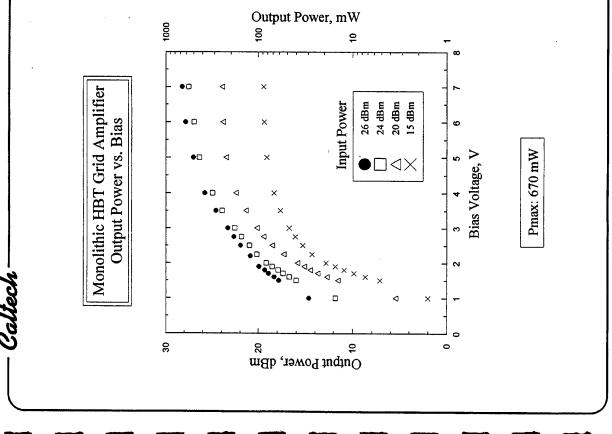






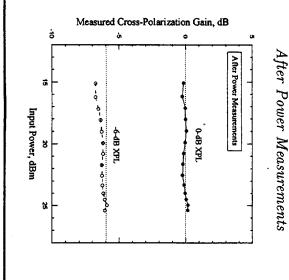


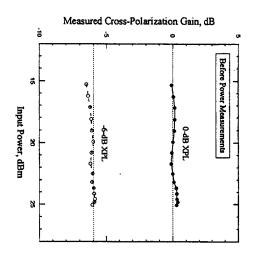




45°-Polarizers 45°-Polarizers -6-dB 45° Polarizer 0-dB 45° Polarizer

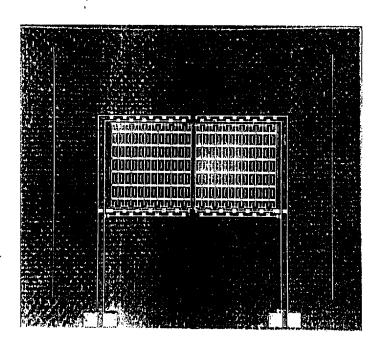
Before Power Measurements

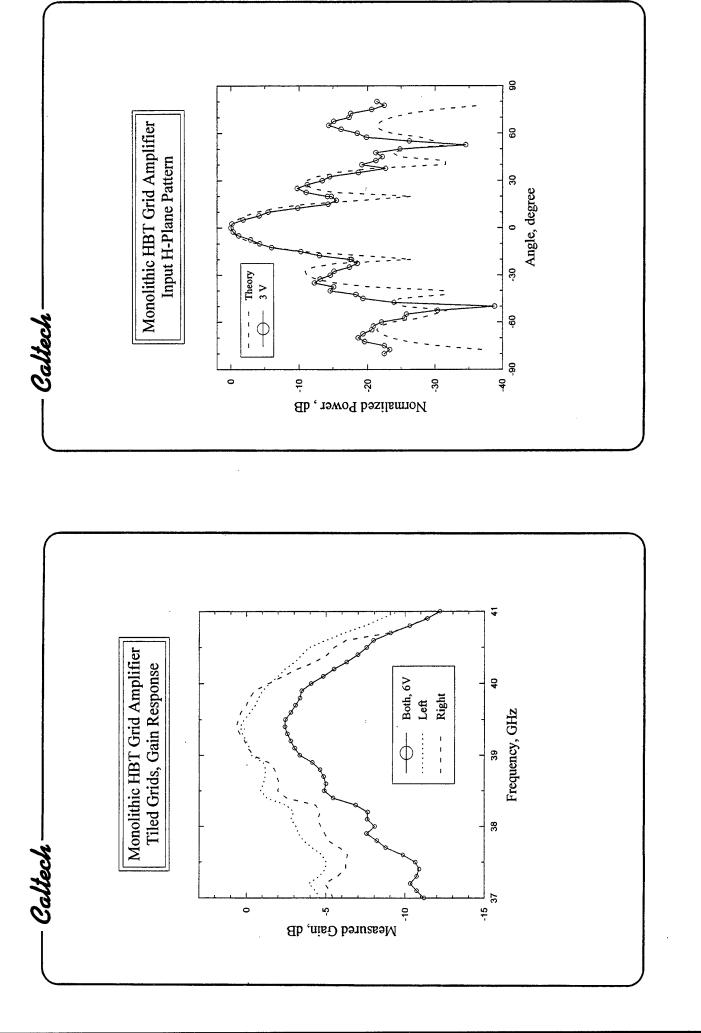


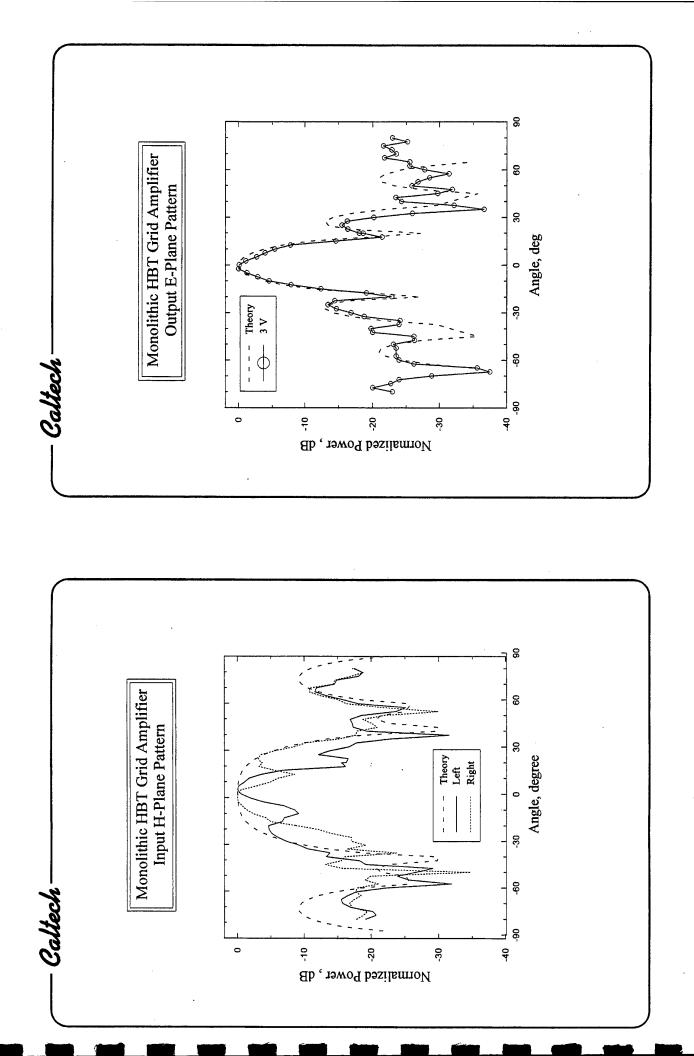


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$Tiled\ Monolithic\ HBT\ Grid\ Amplifiers$







Monolithic HBT Grid Ampliffer
Output E-Plane Pattern
Output E-Plane Pattern

Normalized Power, dB

Normalized Power, and analysis analysis and analysis analysis and analysis analysis and analysis analysis and analysis and analysis and analysis analysis and analysis

Caltech-

Summary of Monolithic HBT Grid Amplifier

Gain Measurement

Gmax: 5dB @ 40GHz 3-dB Bandwidth: 1.8GHz; 4.5%

Power Measurement

Maximum Output Power: 670mW Maximum Power-Added Efficiency: 4%

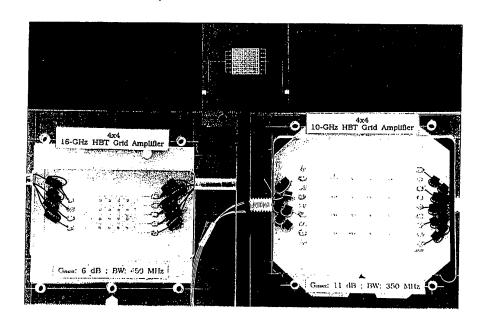
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Comparison of 3 HBT Grid Amplifiers

Design Frequency, GHz	10	16	40
Max. Gain, dB	11	6	5
Period, mm	8	4	1.9
Input Lead, mm	, 0.8	0.4	0.12
Output Lead, mm	0.8	0.5	0.3
Relative Size			

Caltech

3 HBT Grid Amplifiers



2altech

Approaches to High-Power Grid Amplifier

6x6 HBT Grid 670 mW

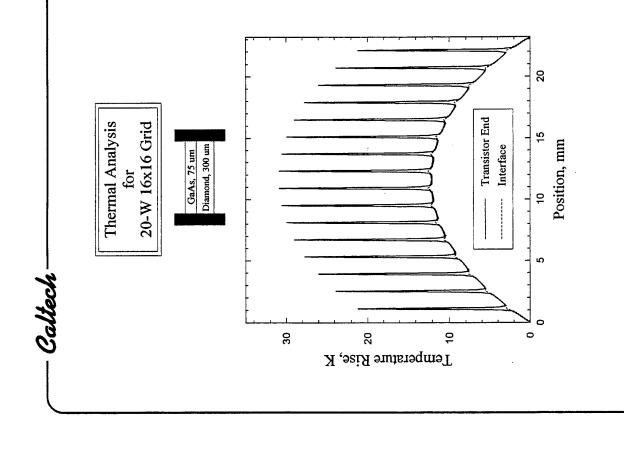


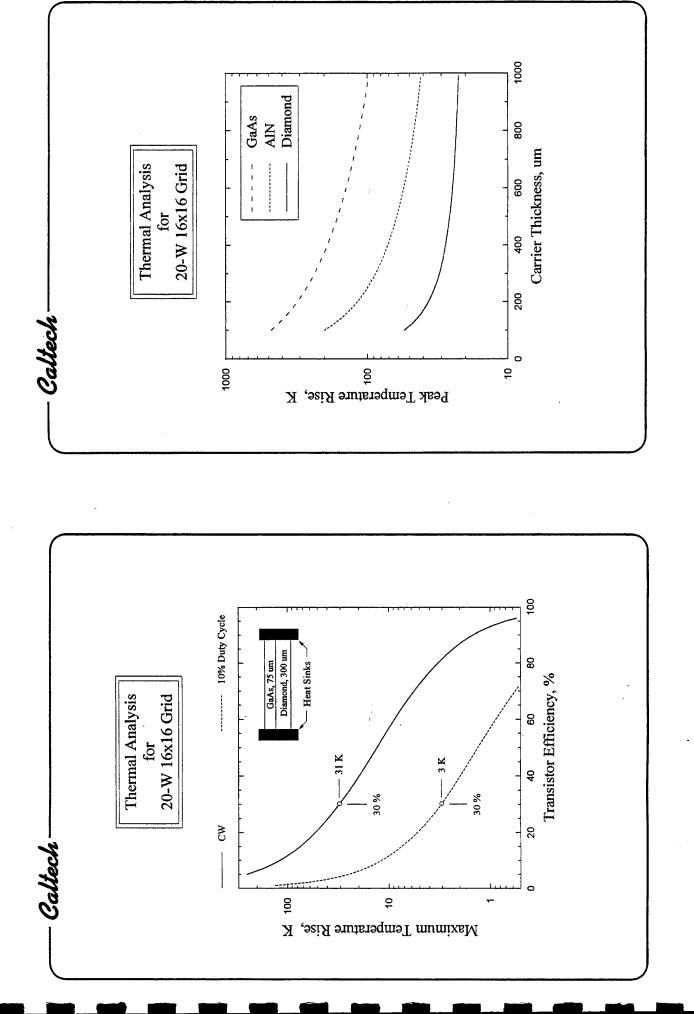
- ☐ Improving Power Capability
 - Samller unit cell
- High-Power & High-gain pHEMT
- ☐ Tiling technology
- ☐ Improving thermal performance

Reduce resistive loss of bias network Thermal carrier, Diamond



16x16 pHEMT Grid with 20 W





A Cascade 20-W Power Amplifier System Micromechanical Switch Beam Steerer Amplifier Output Beam (Controlled by Steerer) PBG Crystal PBG Crystal Crystal

Terahertz Technology Group

Department of Cybernetics
The University of Reading

Berks., UK



J W Bowen

System Characterisation Issues for Integration

Parameters of interest:

- System performance
- S-parameters of active and passive devices
- Mixer, detector and source characterisation
- Antenna patterns
- Dielectric constants of materials.

Measuring instruments are either:

- Waveguide-based, or
- Quasi-optical

Active techniques may be classified as:

- Narrow-band, using coherent sources
- Wide-band, using noise sources
- Time domain, using pulsed sources







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The Interface Problem

Measuring THz Integrated Instrument Circuit

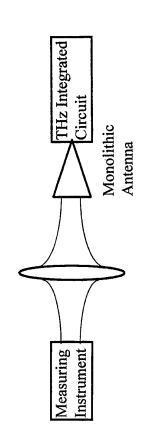
We need some means of coupling power between the integrated circuit to be tested and the measuring instrument.

Problems:

- The waveguiding in the measurement instrument and the integrated circuit under test will be based on different technolgies and fabrication techniques.
- It is often impossible to monolithically fabricate a flange on the integrated circuit that allows direct connection to the measuring instrument.

Solutions:

- Butting waveguides end-to-end: Needs accurately machined end surfaces and requires very accurate alignment.
- reduced height waveguides and there may be mechanical and Dielectric coupling: Works well for full-height rectangular waveguide at the lower frequencies. Does not work for loss problems as the frequency is increased.
- antenna: Appears to be the best solution --- avoids physical Quasi-optical coupling via a monolithically integrated contact to delicate integrated structures.





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System Characterisation Issues for Integration

Beam-mode Decomposition

An arbitrary field in the $z=z_{\rm s}$ plane can be written as a superposition of orthonormal basis functions:

$$u(x, y; z_s) = \sum_{m,n} C_{mn} u_{mn}(x, y; z_s)$$

It is advantageous to choose Hermite-Gaussian or Laguerre-Gaussian functions as the basis functions.

The Hermite-Gaussian function of order m, n is

$$u_{mn}(x, y, z) = \left(2^{m+n-1}\pi m! n!\right)^{-1/2} \frac{1}{w}$$

$$\cdot H_m\left(\sqrt{2} \frac{x}{w}\right) \cdot H_n\left(\sqrt{2} \frac{y}{w}\right)$$

$$\cdot \exp^{-\frac{x^2 + y^2}{w^2}} \cdot \exp^{-\frac{x^2 + y^2}{2R}}$$

The arbitrary real constants w, R and Θ can be freely chosen to $\exp i(m+n+1)\Theta$

give, for example, a good fit to the field with the minimum

number of Hermite-Gaussian functions.

an arbitrary paraxial beam, arising from the field in the source-It can be shown that the field in any constant - z cross-section of Hermite-Gaussian functions and, further, that the propagating field can be considered to be a superposition of beam-modes. plane $z = z_s$ can similarly be described by a superposition of



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$$u(x,y,z) = \sum_{m,n} C_{mn} u_{mn}(x,y,z)$$

The beam-modes $u_{mn}(x, y, z)$ take the form of the Hermite-Gaussian function above but w, R and Θ vary with z (the propagation direction) as:

$$w^2 = w_0^2 + \left\{ 2(z - z_0)/kw_0 \right\}^2$$

$$R = (z - z_0) + \left\{ k w_0^2 / 2 \right\} / (z - z_0)$$

$$\Theta = \tan^{-1} \left\{ \frac{kw^2}{2R} \right\} + \Theta_0$$

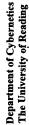
$$= \sin^{-1} \left(1 + \left\{ \frac{kw^2}{2R} \right\}^{-2} \right)^{-1/2} + \Theta_0$$

w describes the width of the beam, which takes a minimum value w_0 at the beam-waist located at $z=z_0$.

R describes the radius of curvature of the spherical wave-front.

© governs the phase-slippage between successive modes relative to an on-axis plane-wave.







System Characterisation Issues for Integration

It is a property of complete orthonormal sets of functions that the coefficients C_{mn} in the superposition that describes the arbitrary field $u_A(x,y;z_s)$ in the plane $z=z_s$ can be determined from the integral

$$C_{mn} = \iint u_{mn}^*(x, y; z_s) \cdot u_A(x, y; z_s) dx dy$$

Thus, for an antenna with a theoretically calculable field in a near-field plane, usually an aperture, this field can be decomposed into Hermite-Gaussian functions by evaluation of the above integral.

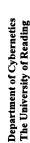
The launched beam will be a superposition of beam-modes described by the same C_{mn} .

The values of w, R and Θ can be chosen for maximum simplicity and computational economy.

For example, in the case of a corrugated feed-horn (Wylde, Proc. IEE, vol. 131, pt.H, no.4, pp. 258-262, 1984) the field at the horn aperture has a spherical wave-front with a radius of curvature equal to the length of the horn. Thus, simplicity dictates that we should set R equal to its length and ⊕ equal to zero.

By iteration, Wylde determined the value of w which maximised the coefficient of the fundamental of the set of functions and thus the power carried by the fundamental beam-mode (98% of the total, with w = 0.6435 x aperture radius).





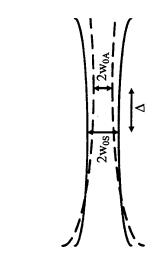


determine the location and size of the beam-waist, which is the

same for all modes in a superposition.

If R and w at any point in a beam are known it is possible to

Beam-mode Coupling



The far-field of an antenna is related to its near-field by Fourier

transformation.

The Fourier transform of a Hermite-Gaussian function is, itself

a Hermite-Gaussian function.

Therefore, if the amplitude and phase far-field patterns of an

antenna are known, it is possible to carry out a beam-mode decomposition in a similar manner to in the near-field.

Relative amplitude and phase of the signal coupled from beam S

to beam A is given by the coupling or overlap integral between

the fields of the two beams, $u_S(x, y, z)$ and $u_A(x, y, z)$, over any constant z plane through the beams, c.

 $\langle u_A|u_S\rangle = \iint_c u_A^*(x,y,z) \cdot u_S(x,y,z)dx \ dy$

The result is independent of the plane of integration.

If u_A and u_S represent two co-axial fundamental beam-modes the amplitude coupling integral becomes

$$\left|\left\langle u_A|u_S\right\rangle\right| = \left(k\overline{w_0}\right)^2 \left\{\left(k^2\overline{w_0^2}\right)^2 + \left(k\Delta\right)^2\right\}^{-1/2}$$

 $\frac{--}{w_0}$ is the geometrical mean of w_{0A} and w_{0S}

 w_0^2 is the mean of w_{0A}^2 and w_{0B}^2



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Astigmatism Correction

Similar expressions exist for laterally and rotationally displaced fundamental beam-modes.

of the Symposium on Quasi-optics, New York, 1964, Microwave More general expressions which quantify the coupling between beam-modes of different orders are given in H. Kogelnik, Proc. Research Institute Symposia Series, vol.14, pp. 333-349, Polytechnic Press, 1964.

The ideal situation would be to have perfect coupling between the test beam and that launched by the antenna on the integrated circuit under test.

Even so, it is likely that there will be some reflection at the antenna and calibration procedures will have to be gone through to de-embed device parameters.



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Possibilities:

- 1. A train of two cylindrical lenses acting orthogonally on the E and H planes.
- 2. A single non-axially symmetric lens.
- 3. An off-axis spherical mirror.

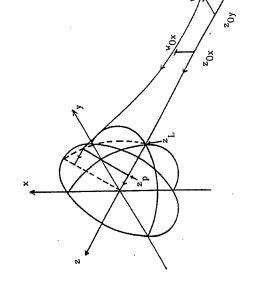
1 and 3 give an elliptical rather than circular output beam-waist for all but a special-case ratio of astigmatic difference and output beam-waist size.

- 2 is the most difficult to manufacture.
- 3 gives lower throughput losses and freedom from interference

Elapsed phase lens design for astigmatism correction

Astigmatism correction using a spherical mirror

where the second second





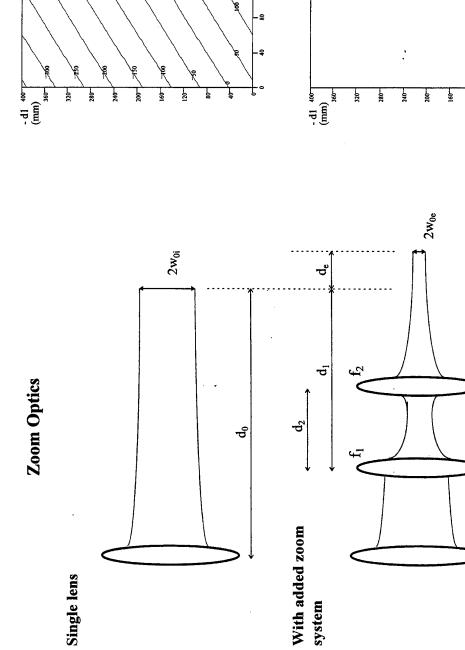


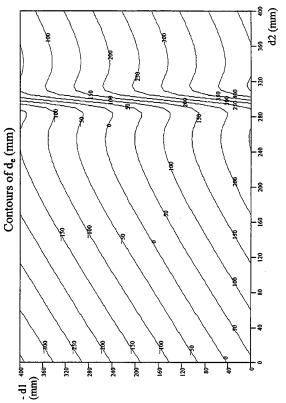


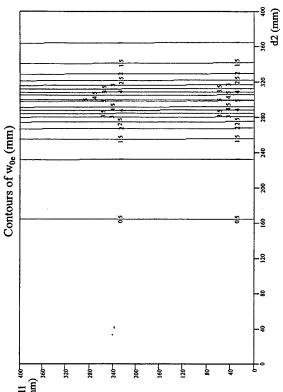


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System Characterisation Issues for Integration







 $f_1=250~\text{mm},~f_2=50~\text{mm},~w_{0i}=25.2~\text{mm},~\text{frequency}=700~\text{GHz}$



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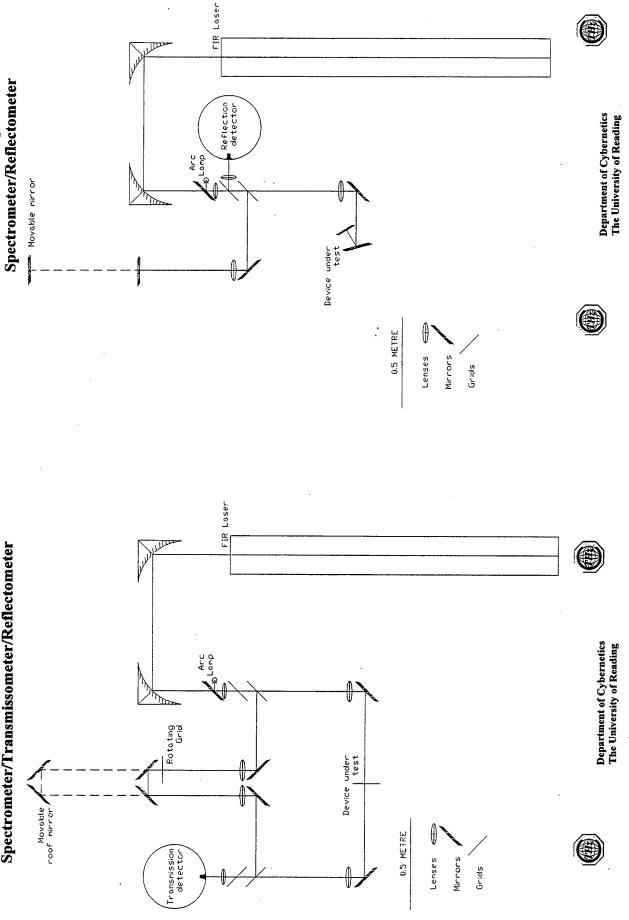
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TINTIN Quasi-optical

TINTIN Quasi-optical Spectrometer/Transmissometer/Reflectometer



Integrated Antennas

by

G M Rebeiz

(No material available.)

TeraHertz Astronomy from Space

Thijs de Graauw Space Research Organisation of the Netherlands(SRON) Groningen, The Netherlands. e-mail: thijsdg@sron.rug.nl

Introduction:

The FarInfrared/SubMm/TeraHz range is the last part of the electromagnetic spectrum to be explored in astronomy. Sofar only parts of this range have been studied, either with a small(60cm) telescope from space or with a larger ground-based telescope(2m-15m) in only narrow atmospheric windows, or not at all. Till today there have been two all-sky survey/explorer space missions: The InfraRed Astronomical Satellite(IRAS) and the Cosmic Background Explorer(COBE). Both made full maps of the entire sky. IRAS covered the IR range from 12-100 microns, COBE extended further, down to the mm range. IRAS with an angular resolution of a few arcminutes, COBE with a resolution of several degrees. The third (F)IR mission is the Infrared Space Observatory(ISO). It covers the 2.5 to 240 micron region with photometers, spectrometers and a near/mid IR camera. Its spatial resolution is given by the diffraction limit of the 60 cm telescope. Since November 1996 ISO is in orbit and produces detailed maps and spectra of selected regions in the IR sky previously mapped by IRAS. It is the first IR space observatory that can make full spectra over the entire wavelength range and thus explores a new dimension of the IR universe.

THz Astronomy from Space

There are now two new major ESA missions planned for the FIR-MM region. These are the Cosmic Background Radiation Anisotropy Satellite(COBRAS) in combination with the Satellite for Measurement of Background Anisotropies(SAMBA), the so-called COBRAS/SAMBA mission, and the FarInfrared and Submm Space Telescope(FIRST).

COBRAS/SAMBA with a 1.5m diameter telescope, will make a full sky survey in about 9 bands between 30 and 900 GHz, with an angular resolution of about 10 arcminutes and a very high precision which is needed for the assessment of the anisotropy of the cosmic background. In order to do this in an accurate way the foreground components of the Galaxy and the contributions of the nearby and distant galaxies have to be subtracted. This, as a sideproduct, will produce detailed maps of the foreground components and therefore extremely interesting data will become available to a wide astronomical community.

FIRST with a 3m diameter telescope excels in the following three areas.

A) It will make very sensitive and very high resolution wideband heterodyne spectroscopy in the 490-1200 GHz of submm lines of important light molecules that have not been detected in interstellar space. The spectral survey will result in a high quality analysis of the chemical composition, physical conditions and dynamics of interstellar, protostellar and

circumstellar clouds, planetary atmospheres and cometary comae.

- B) The most important FIR cooling lines can be studied in heavily obscured star-formation regions in our Galaxy, nearby galaxies and in galaxies in the early universe.
 - C) With a 10-20 arcsec resolution spectrophotometric imaging will be possible at very high sensitivity in the 750-1500 GHz range. FIRST, thus, will be capable to detect very faint condensations in molecular clouds, signatures of dust cocoons of protostars.

The two missions, COBRAS/SAMBA and FIRST are very complementary in respect to their science objectives.

THz Technology for Space

The technology used in these two missions have a large commonality. First of all the direct detection instruments are probably going to use the same bolometers. The radioreceivers however will have very different technology, COBRAS' receivers are based on HEMT amplifiers as their upper frequency is only 125 GHz. FIRST's heterodyne packge will cover 490-1200 GHz. The requirements on the FIRST heterodyne instrument are therefore more challenging. Because of the sensitivity performance of SIS technology FIRST will use these 4K cooled receivers. The back-end spectrometer section is more demanding than the ones used at ground-based radio observatories. An overview of the preferred characteristics of a spectrometer for FIRST is given in the table.

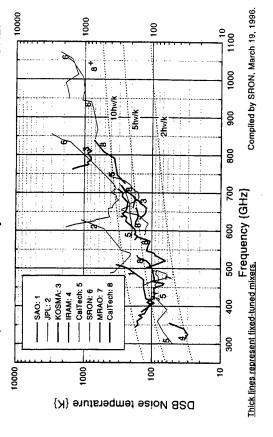
Presentation

In the presentation an overview will be given of the main scientific goals in present astronomy. From this the requirements on the instrumentation will be derived. The development status of the instrumentation and its components will be discussed. An overview of the present sensitivities of Submm mixers will be given. See figures. The most critical items in the development of space qualified receivers (Local Oscillators) will be discussed. Also results of experiments to establish the space environment compatibility of the key technologies will be reported.

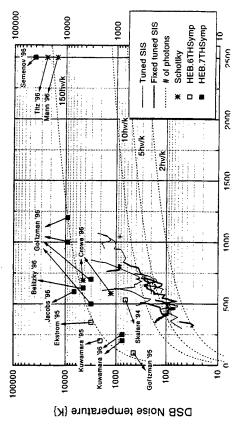
Table 1: Specification of the IF/Spectrometer for a planar receiver for Astronomy.

	Galactic Sources	ources			Extra Ga	Extra Galactic Sources	urces	
Specification	Astro km/sec	400 GHz	1500 GHz	2000 GHz	Astro 400 km/sec GHz	Í	1500 GHz	2000 GHz
Instantaneous bandwidth	100	130 MHz	200 MHz	130 MHz 500 MHz 650 MHz 1000 1.3 GHz 5 GHz 6.5 GHz 6.5	000	1.3 GHz	S GHz	6.5 GHz
Spectral Resolution	-	130 KHz	500 KHz	130 KHz 500 KHz 650 KHz 10	01	13 MHz	13 MHz 50 MHz 65 M	65 MHz
Number of Channels		1000	1000	0001		100 100	100	100

Sensitivity of SIS Heterodyne Receivers above 300 GHz.



Sensitivity of SIS, HEB and Schottky Heterodyne Receivers.



Terahertz Measurements from Satellites

by

B Carli

(No material available.)

Abstract of Paper for

NATO ASI. " New Directions in Terahertz Technology" (July 1-11, 1996, Chateau de Bonas, Toulouse)

SPACECRAFT APPLICATIONS OF TERAHERTZ TECHNOLOGY

* Matra Marconi Space, Bristol, UK

The Terahertz bands offer exciting opportunities for the remote sensing from space of atmospheric consistents with great importance for the planning of industrial and commercial activities. To exploit these opportunities requires the development of new sensor devices combining robustness with decreased dimensions and many developments of integrated receiver and antenna components are now in progress.

The paper will survey the range of studies and technology developments aimed at remote sensing applications in the milimetre, submillimtere and terahertz frequency bands. The emphasis will be on the critical technology needs and on meeting both the performance and spacecraft interface requirements. The range of technologies described will cover components from antenna to intermediate frequency outputs with some comments on the data analysis equipments in the instrument back end. The heritage in millimetric instruments will be treated to explain the common and novel features of Terahertz applications.

Particular emphasis will be given to the newer integrated technologies and the developments now in progress and foreseen will be summarised in the context of their application to spacecraft instruments being planned for applications such as the sensing of atmospheric Outlines of Terahertz instrument programmes and design studies will be included. processes relevant to the ozone cycle.

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FROM

p-Ge and p-Si Lasers for Terahertz Applications

by

T Wenckebach

TU Delft The Netherlands

Abstract

- the p-Ge IVB laser is based on a population inversion (PI) between the light hole and heavy hole band.
- the PI is achieved by applying strong crossed electric and magnetic fields at helium temperature.
- a Monte Carlo simulation is used to investigate the small signal gain dependency on the non-orthogonality of **E** and **B** fields.
- by tuning the E and B fields a few degrees from orthogonality the small signal gain is significantly decreased.
- this is duc to the acceleration of the light holes out of the passive region in k-space below the optical phonon energy, where the PI exists.
- the feasibility of achieving active mode-locking in an IVB hot hole laser by using this idea for gain modulation is discussed. It turns out, that very short far infrared pulses of 10-100 ps may be obtainable in this way.
- some first experimental results are presented. Under certain conditions lasing can be stopped by applying an RF field at small additional contacts along the magnetic field direction. However, when the RF frequency is made equal to half the axial mode spacing, the lasing reappears.

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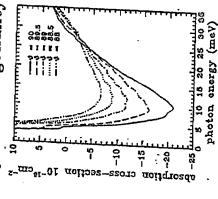
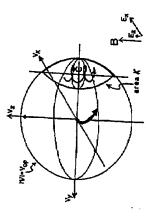


Figure 5: a) Small signal gain for different angles between E and B. B = 1.37[110]; $\vec{\mathbf{E}} = 2\text{kVcm}^{-1}[001]$; $N_I = 1.3 \cdot 10^{14}\text{cm}^{-3}$, $p_0 = 7 \cdot 10^{13} \text{cm}^{-3}$; T = 10K; e, $\parallel \mathbf{E} \times \mathbf{B}$.

Conclusion: a few degrees non-orthogonality destroys population inversion completely, but WHY?



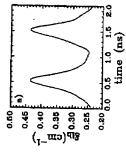
cumulation region in velocity space. The holes are accelerated Figure 6: The spindle-shaped (in spherical approximation) acby the additional electric field | B and escape from the accumulation region along the helical orbits drawn. Thus the PI diminishes (see Fig. 2) and the small signal gain drops.

Possibility of an actively mode-locked p-Ge IVB laser

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- we use this effect to achieve an actively mode-locked IVB laser by gain modulation
- ic field with a frequency equal to cavity roundtrip frequency (≈ 500 This is done by applying an additional RF field parallel to the magnet-



lated part of the p-Ge crystal due to the direct IVB transition during one (cosine) period of the RF $T_{\rm e} = 10 {\rm K}$, $E_{\rm RF}^0 = 40 {\rm V cm}^{-4}$, $N_I = 2 \times 10^{14} {\rm cm}^{-3}$. $g_{\rm ih}$ is modulated considerably at the second harmonic of the RF frequency $f_{\rm in} = 500$ MHz but is more 'peaked': at least the first 8 Fourier Figure 7: a) Small-signal gain g_{ll} for far-infrared radiation $(h
u=12 ext{meV}$, $\mathbf{e}_
u\parallel\mathbf{B})$ in the modufield, as calculated from the Monte Carlo simulation. $\mathbf{E} = 2k V cm^{-1} \| [111]$ and $\mathbf{B} = 1.3T \| [011]$ coefficients have to be sampled to represent gia.

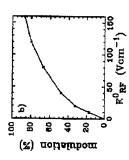


Figure 8: peak-to-peak gain modulation depth versus amplitude Ego of the RF field.

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Conclusions:

- a relatively small RF field already yields 30-50 % peak-to-peak gain modulation.
- ullet from the linewidth $\Delta f pprox 3$ THz of the IVB transition, we can estimate the steady state pulsewidth:
- if inhomogeneously broadened: $\tau_{p,ss} \approx 0.2 \text{ ps.}$
- if homogeneously broadened: $\tau_{p,ss} \approx 9$ ps.
- from saturation studies of the IVB transition [1], it is concluded
- the passive material is inhomogenously broadened, with $\delta \nu_{\rm inh} \approx 200 {
 m cm}^{-1}$ and $\delta \nu_{\rm hom} \approx 7 {
 m cm}^{-1}$
- the active material (i.e. lasing, with strong B L B fields applied) is homogeneously broadened, due to:
- * transit-time broadening [1]
- * a small non-orthogonality of E and B [2]
- assuming a stable laser operation of $10^3 10^4$ roundtrips before laser saturation, we may still expect very short far infrared pulses of about 10 to 100 ps.

Experimental Results

- sample is mounted in Voigt configuration (long axis perpendicular to B).
- crystallographic orientations: $\mathbf{E} \parallel [1\overline{1}0], \mathbf{B} \parallel [11\overline{2}].$
- an external cavity is constructed by pressing a capacitive mesh (g = $30\mu\text{m}$, $2a=1\mu\text{m}$ on a Si substrate) and a flat copper mirror (separated by a thin Teflon film) directly to the laser crystal.

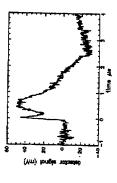


Figure 9: characteristic signal on Schottky diode, $au=2.5\mu\mathrm{s}$, $V=800\mathrm{V}$, $B=0.9\mathrm{T}$.

- \bullet the pulselength is limited to approximately 5 $\mu \mathrm{s},$ due to heating of the sample.
- emission area;

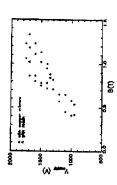


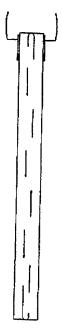
Figure 10: range of electric and magnetic field, where the crystal is lasing.

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Application of an additional RF field

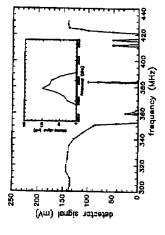


- electrical contacts have been made for the application of the • at one side of the laser crystal, small $(1 \times 10 \text{ mm})$ additional RF field | B.
- the resistance between the additional contacts at RF frequency 100 MHz is approximately 10 (no magnetoresistance !).
- thus an impedance matching circuit has been designed to 200 - 500MHz amplifier into the laser crystal. couple the RF power from a 50Ω, 100W,
- by applying the RF field continuously, lasing is stopped at an RF power of only a few watts.
- for a gated RF pulse of a few hundred microseconds the behaviour is identical, even if the RF burst is applied before or after the high voltage pulse. Thus this small signal gain decrease is due to additional sample heating. However, it allows us to measure the frequency dependence of the impedance matching circuit.
- for a gated RF pulse of only a few microseconds during the laser emission, there is no significant decrease of laser intensity, even at maximum RF power.

However, if:

14:26

to the magnetic field axis (z-axis), such that $E_z = E_z^0 + E_z^\omega$. As a • the sample electrodes are tilted approximately 2 degrees with respect ed strongly at the RF frequency (so no longer at the second harmonic consequence the small signal gain has been decreased and is modulat-



RF frequency; the estimated RF power dissipated in the laser crystal is approximately 60W. Lasing is prolibited by the RF field between 355 and 420 MHz, but reappears when the RF frequency is tuned to approximately 384 MHz (see fast). It is noted that the lasing around 360 MHz and 417 Figure 11: detector signal on Schottky diode $(\tau-2.5\mu s,V=800\mathrm{V},B=0.9\mathrm{T})$ as a function of the MHz is very unstable and is therefore ascribed to small additional resonances close to the resonance borders of the impedance matching circuit.

Estimated cavity roundtrip frequency (or longitudinal mode spacing):

$$\nu_{RT} = c/2L' \approx 765 \mathrm{MHz}$$

with
$$L' = n_{Ge} * L_{cryst} + n_{Si} * d_{mesh} + n_{Teflon} * d_{Teflon}$$
.

- THUS: there is a clear resonance at half the cavity roundtrip frequency
- HOWEVER: we did not observe a corresponding modulation of laser intensity, when monitoring the laser pulse on a (400 MHz bandwidth) digital oscilloscope.

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However, if:

- the sample is tilted approximately 2^o with respect to the **B** axis, such that $E_z = E_z^0 + E_z^\omega$. Thus the gain is smaller and modulated at the RF frequency.
- \bullet The small signal gain is almost constant up to $4^{\circ},$ sample tilt contrary to theoretical expectations !
- This is probably due to doping inhomogeneity, which causes an average mon-orthogonality of ${\bf E}$ & ${\bf B}$ of a few degrees

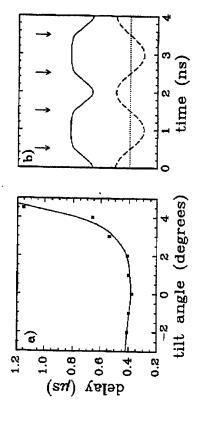


Figure 12: a) Delay of laser output pulse from the beginning of the HV pulse versus sample tilt augle. b) gain-modulation scheme for the tilted sample: the solid line shows the response of the small-signal gain to a strong 500MHz RF field along B (dashed line), as expected from a). The arrows indicate when a pulse travelling through the resonator at a cavity roundtrip frequency of 1GHz has to pass the modulator in order to be selectively amplified.

- The small signal gain is constant up to 4°, contrary to theoretical expectations!!
- This is probably due to doping inhomogeneity (possibly enhanced by space-charge effects ?!), which cause an average non-orthogonality of **E** & **B** of a few degrees

Conclusions

- the application of an RF field along the magnetic field direction has a significant effect on the lasing behaviour of a p-Ge hot hole laser.
- this is due to acceleration of light holes out of the accumulation region below the optical phonon energy in k space.
- the additional sample heating effect is made relatively small by gating the RF burst up to a few \(\textit{\mu}\)s.
- we observed a reappearance of laser emission, when an RF field is applied at HALF the cavity roundtrip frequency. This is observed only if the sample is tilted a few degrees.
- this can be understood from the behaviour of small signal gain, averaged over the laser crystal, as a function of sample tilt.
- The observed effect is a very strong indication for mode locking. Further investigations are necessary to demonstrate it in the time- and frequency domain.

P.009

Likely Future Instrumentation Requirements at Terahertz Frequencies

by

D Rytting

(No Material supplied.)

Potential Applications of Terahertz Systems for Collision Avoidance and Related Areas

by

H Brugger

(No Material supplied.)

What Future for Wireless Telecommunications Beyond 60 GHz?

2

D Wake

(No Material supplied.)

Nato Advanced Study Institute

New Directions in Terahertz Technology

Château de Bonas, near Toulouse, France

July 9th, 1996, 9.30-11.30

VECTOR MEASUREMENTS FROM 8 TO 800 GHz

Philippe Goy, Michel Gross,

and

Département de Physique de l'ENS 75231 Paris Cedex 05, France, Laboratoire Kastler-Brossel tel: 33 1 44 32 34 18 24 rue Lhomond, fax:43 35 00 76

Abstract

Part I. Presentation of the basic principles and evolution, over a period of about ten years, of a Millimeter Vector Network Analyzer.

Part II. Antenna measurements, where the phase information appears to be very useful, illustrate one of the first applications of the MVNA

Part III. Fast and accurate dielectric characterizations are performed by various methods involving phase measurements.

Illustrations of MVNA use will be presented on the Analyzer itself, in

action.

Fig.1.1.

All Millimeter Waves analyzers produce the Millimeter Waves frequencies Fmm by frequency multiplication, in a Schottky diode Harmonic Generator HG, from a centimeter source at the frequency F1.

Detection is firstly operated by harmonic mixing, the Schottky diode Harmonic Mixer HM being powered from a 2nd centimeter source at the frequency F2 (Fig.I.1). Finally a heterodyne receiver works at the frequency Fif (in the MHz range) such as:

produced by 8-18 GHz sweepers, the 2nd sweeper being maintained at a constant The offset frequency f was chosen close to 3 MHz, and the heterodyne receiver was distant frequency from F1, via a PLL control: F2 = F1 - f

a 0.1-30 MHz traffic radio-receiver. The tuning of this receiver, at frequencies close to 3 MHz x N, permitted to select the harmonics N such as:

$$N = N1 = N2$$
 (1.5.)
Fif = $N \times f$ (1.6.)

and mobile millimeter heads (at the bottom left of the picture). The large dynamic The **Scalar** Analyzer, shown Fig.I.2 at an exhibition in 1988, was including the short waves radio receiver (at top left). Called MSNA, it could use very simple, compact range available made the MSNA a good tool for applications such as antenna measurements.

Analyzer became a Vector Analyzer, called MVNA-8-350. The basic configuration of In 1989, the Scalar heterodyne receiver was replaced by a Vector one, and the the MSNA is used also for the MVNA (Fig.1.3). From the 1.1-6 above equations, one can deduce the phase Φ relationship:

$$\Phi i f = 1 N1 \times \Phi 1 - N2 \times \Phi 2 I. \tag{1.7.}$$

Since the 2nd sweeper is phase-locked onto the 1st, the noise components of the phases Φ1 & Φ2 of the two sources are the same:

$$= \Phi 2, \tag{1}$$

(Eq.I.7.) tif represents nothing but the DUT phase. There is no need for a parallel detection chain, which appears to be necessary in all previous millimeter vector analyzers, for supplying the phase reference onto the vector receiver. This new and very simple principle (1989) has been patented (EEC, USA, Japan). Due to it, millimeter heads remain the same, compact and light, as for the scalar analyzer. In and since the harmonic orders N1 & N2 have the same value, the detected phase particular, transmission measurements do not need any directional coupler (which nardly exist in the submillimeter).

Fig.1.4.

In the diagram Fig.I.4 is shown the maximum possible working frequency of successive analyzers MSNAs. & MVNAs. Improvements have been done by reducing the noise, and also by increasing the microwave powers, by improving Schottky multiplication efficiency. It is also possible to associate a millimeter Gun source at the required frequency. This is called ESA-0 (External Source Association nr0) when the Gunn is used directly, and ESA-1 (External Source Association nr1) when the Gunn feeds a Multi-Harmonic Harmonic Generator (Schottky diode multiplier). The use of a millimeter source (a Gunn around 100 GHz), instead of the 1st centimeter sweeper, produces a larger power at a given submillimeter frequency, since the harmonic rank N, necessary to reach this frequecy by multiplication, can be smaller. Similarly, a reduction of the noise is obtained from the use of a 2nd Gunn of the detection side as Local Oscillator of the Schottky Harmonic Mixer (called ESA-2), instead of the 2nd centimeter sweeper.

-ig.l.5.

In Fig.I.5 is shown the typical dynamic range of the MVNA-8-350, without or with extensions ESAs. ESA-1-95 means a Gunn centered at 95 GHz, ESA-1-110, centered at 110 GHz.

Fig.1.6.

Fig.1.6 shows the very schematic diagram of the MVNA, with the orders of magnitude of the powers along the source/detection chain. The values at the center (where the observed dynamic range S/N is of the order of 120 dB) correspond to 50-70 GHz, without ESA, and to ca 400 GHz, with ESA-1 & ESA-2, as well.

in 17.

Fig.1.7 is a table giving all relevant parameters concerning the diagram of Fig.1.6, and explaining the dynamic range observed Fig.1.5.

Fig.1.8.

The Schottky diode of the Multiplier M in the ESA-1 extension is a non-linear device. Controlling the feeding millimeter power by a calibrated attenuator K (Fig.I.8) permits to control the power emitted from this Multiplier.

Fig.1.9

Mixer HM-D. Harmonics three M=3 and above are measured by using the extension dependence is very low, around 0.2, so that a Gunn increase of 1 dB leads to a 220 Harmonic M=5 presents a 4.72 slope, M=6 a slope 4.57, M=7 a slope 5.17. The deviation of the experimental points from linear extrapolation of the M=3 curve below the 40 dB position of the attenuator most probably comes from the unaccurate The MVNA-8-350's very large dynamic range and good linearity will permit to calibrate the Output/Input power law. This could be very interesting for the understanding of the frequency multiplication efficiency. Moreover, the sensitivity of the heterodyne receiver permits to observe good signals even for low-efficiency multipliers, far below the nanowatt level. In Fig.I.9 are shown the observed output signals, for harmonics 2 to 7, at the frequencies 220 to 770 GHz generated from the Multiplier M of the extension ESA-1-110. The absolute maximum powers (attenuator at 0 dB) of harmonics 2-5 have beeen measured on a bolometric probe: 3.7, 1.6, 0.92, 0.15 mW, respectively. Then harmonic two M=2 is detected by the Harmonic ESA-2-110 as a detector. Close to the maximum incident power (0 dB at the input Attenuator knob), the slope of each curve in Fig.1.9 indicates the possible gain which could be obtained from a more powerful 110 GHz input (we have around 20 mW). For harmonics 3-5, the slope is close to one. One dB gain in Gunn gives about one dB more microwave after mutiplication. For harmonic two (M as a doubler), the GHz power increased by about 0.2 dB only. After desaturation of the Schottky Multplier, which occurs between 15 and 20 dB at the attenuator, the Output/Input power law presents a slope which is just the harmonic order M, for M=2, 3, and 4. calibration at >40 dB values. With a recalibrated attenuator, or, with two calibrated attenuators in series, used in their "good" range (below 40 dB), one can have a set (220, 330, 440, 550, 660... GHz) of controlled small powers (eventually below the pW, disks at Fig.I.9, bottom), which could be used in sensitive receiver tests. preferably,

Fig.1.10.

The front panel of the microwave part of the first version of the Vector Analyzer MVNA-8-350-1 (Fig.I.10) is exactly similar to the one of the Scalar Analyzer MSNA (Fig.I.2): there is one output for the source side, and one output for the detection side. Each of the HG and HM millimeter heads can be biased, or self-biased ("short" switch position). The current, applied or due to the rectified centimeter microwave, appears in the galavanometers (full scale 25 mA).

Fig.I.11.

The front panel of the second version of the MVNA, model MVNA-8-350-2 produced since 1995, is shown in Fig.1.11, and is to be compared to the previous model Fig.1.10. MVNA-8-350-2 vector receiver is a dual-channel one. Two Harmonic Mixers, HM1 & HM2, can work in parallel. This possibility is very useful for measuring transmission-reflexion at the same time, or for measuring antennas, and then compensate any phase or amplitude drift on a long base by ratioing the signal obtained onto the tested antenna by a signal from a control antenna.

Fig.I.12.

As an exemple of the use of MVNA-8-350-2, Fig.I.12 shows the compensation of phase drift over three hours at 96 GHz.

Fig.1.13.

The model MVNA-8-350-2 can be used in a dual-millimeter frequency configuration. The only restriction is that the two frequencies Fmm1 & Fmm2 must be harmonics N1 & N2 (integers) of the same centimeter frequency Fcm (with 8<Fcm<18.75 GHz) from the MVNA sweeper. The centimeter power of this sweeper, split in a 3 dB coupler, generates Fmm1 = Fcm x N1 in HG1, and Fmm2 = Fcm x N2 in HG2. The two channels of the receiver are tuned on the different Fif from HM1 & HM2. In the example shown Fig.1.3 top, at the upper frequency of the sweep, one has Fcm = 12 GHz. The millimeter frequencies are Fmm1 = 36 GHz, and Fmm2 = 96 GHz, with N1 = 3 and N2 = 8. These harmonics were chosen in order to obtain the main frequencies of interest on the battle field, around 35 and 95 GHz. The obtained dynamic range (Fig.1.3 top) is not as good as it could be in standard working conditions, since the second harmonic, N2 = 8, is larger than the value N = 6 which is the best choice for 96 GHz generation.

Fig.1.13 bottom shows that the two detected different millimeter frequencies are quite ndependent (there is no crosstalk), when their power levels are modified via attenuators.

in.1.14

The microwave front panel of the model MVNA-8-350-4 (Fig.I.14), created in 1996 for 4-S Parameters measurements, is similar to the model MVNA-8-350-2 (Fig.I.11), plus two outputs: "Source 1" (for HG1) and "Source 2" (for HG2). The HG centimeter sweeper is sent alternatively to HG1 and HG2.

Fig.1.15.

A MVNA-8-350-4 is installed at ENSTBr Telecom-Bretagne, Brest University, Prof. S. Toutain (Fig.1.15).

Fig.1.16.

The detail of the millimeter heads used in the Ka band (26.5-40 GHz) at ENSTBr is shown on Fig.1.16. From left to right, the millimeter heads are: HG1, HM2, HM1, HG2. When HG1 is powered, HM1 gives S21 and HM2 gives S11. When HG2 is powered, HM1 gives S22, and HM2 gives S12.

Fig.1.17.

In the millimeter, and especially in the submillimeter waves domain, most of the measurements do not involve a complete calibration of the error terms, which is possible only with the full reverse analyzer such as MVNA-8-350-4. With a single source-single detection configuration, complete calibration is possible for reflexion (S11 and S22 are measured in two steps). Transmission calibration (S21 & S12) is obtained by looking at the signal through an attenuator. This calibration is, most of the time, good enough. However, it is not perfect (at the typical +/-0.2 dB level), especially for low insertion, where the complete calibration must be used, if possible. Fig.1.77 shows 4S-Parameter measurements with the W-band WR-10 setup in a 90-100 GHz sweep, through a WR-15, 4-inch (101.6 mm) long waveguide. This waveguide presents a small insertion loss. The mismatches at its two ends create an interference pattern, like in a Fabry-Pérot resonator.

S11 (reflexion from port 1) is shown at top left onto the Smith chart. S12 (transmission from port 2 to port 1) is shown at top right, linear scale. S21 (transmission from port 1 to port 2) is shown at bottom left, polar plot.

S22 (reflexion from port 2) is shown at bottom right, log (dB) scale.

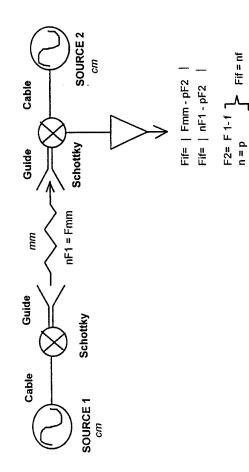
Fig.I.18.

The heterodyne vector receiver operates several downconversions of the detected millimeter signal. The last frequency has been chosen ca 500 Hz, allowing a low noise level and a good dynamic range, like the 99+/-10 dB observed in the 72-112 GHz interval, Fig.I.18, top. Such a frequency does not permit fast sweeps, and the 500 points sweep lasts for typically 30 s. A new version (1996) of the receiver downconverts the signal to ca 10 kHz. Then measurements can be about ten times faster (500 points obtained in 3 s), with, naturally, a decreased dynamic range: 89+/-10 dB in the 72-112 interval, Fig.I.18, bottom. The fast receiver can recover the best dynamic range, by slowing down the sweep, and averaging.

Fia.1.19.

For testing the fast receiver in the most difficult case, one observes a high-Q (Q = 160,000) Fabry-Pérot cavity by transmission. The width of resonances is of the order of 0.6 MHz. The first sweep, Fig.I.19, top, is made in 60 s with ten thousands points, which means 0.15 MHz steps, so that the resonances cannot be missed. The second sweep, Fig.I.19, bottom, is obtained in 3 s, with 500 points. The detected signal is quite satisfactory.

Let us remark that in the fast sweep, resonance details are shown despite the fact that the steps, now 3 MHz, are larger than the cavity width. Contrary to the other millimeter vector analyzers, MVNA-8-350 uses sweepers, not synthesizers, so that all frequencies are really emitted during a sweep.



● 1985, PLL F2/F1 SCALAR ANALYZER (with short wave radio) Fig. I. 1.

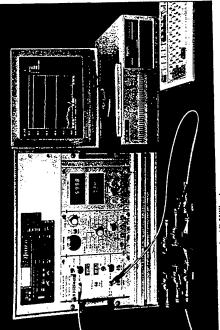


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MILLIMETRIC FREQUENCIES



The 16-250 GHz analyser by AB Millimetre.

Fig.1.2

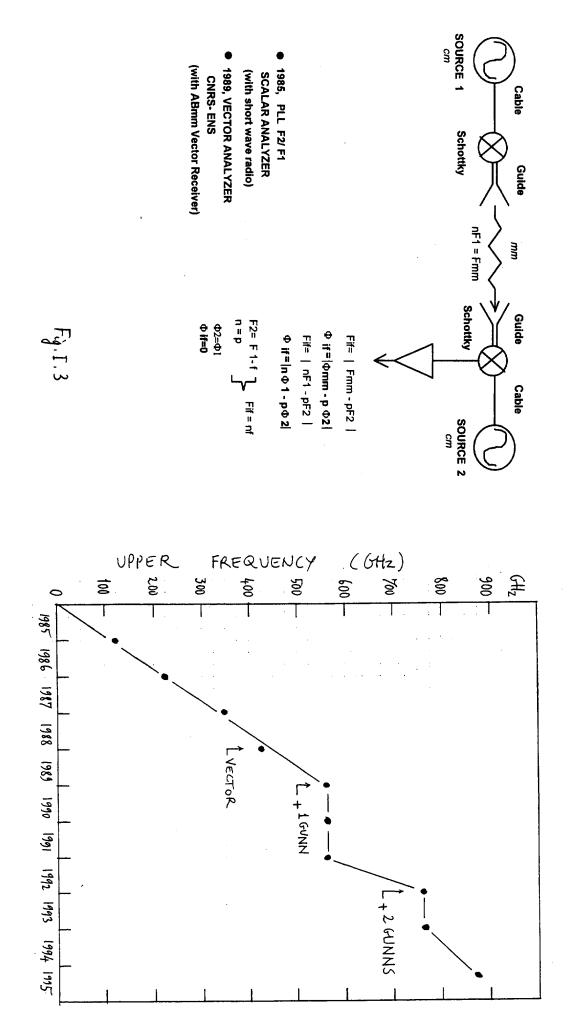
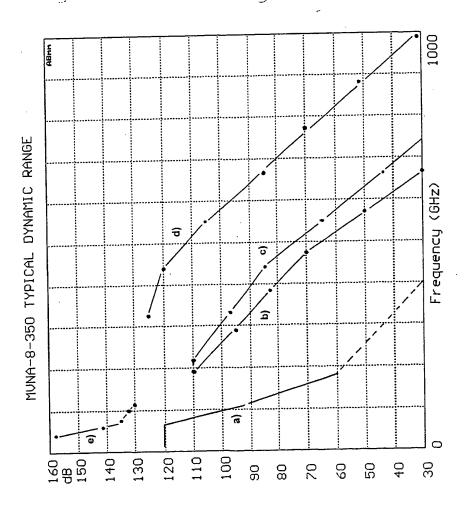


Fig. 1.4.



- a) MVNA-8-350 alone,
- b) with ESA-1-95 extension,
- c) with ESA-1-110 extension,
- d) with ESA-1-110 + ESA-2-110 extensions,
- e) with different ESA-0 extensions.

HG From HM Fit Vector

REGISTAL

Phase Control Phrent Chesens 1989

fmm = 0 dBn (1 mW) L = 30 dB PN = - 150 dBm (10 W) at 20 pts/s => 5N= 120 dB MVNA-8-350 dlone: 5,85_=8-18042 succepers

with ESA-1: S1= mm Gunn

with ESA-12ESA-2: 514 Si= mm Gunns

Fig. 1.6.

764 665 299 045 550 247 FREQUENCY 440 330 950 990 380 585 220 961 011 56 MULTIPLICATION 9 5 9 OF THE GUNN FREQUENCY -24 -57 | POWER FROM -38 L 0 ন্ ESA-1-95 POWER FROM - 37 78--7.4 -48 5.7 -65 ۲ 7 ESA-1-110 POWER FROM -572? 4 95-SEXTUPLER HM-D CONVERSION LOSS 70 77 49 ≊ 76 25 22 \$ 37 28 82 82 30 ಱ ESA-2-95 SHM (ONV. 42 5773 2 \$ 24 77 3 Z -ERSION LOSS ESA-1-95 SOURCE/ HM-D. DETECTOR DYNAMIC LANGE ď 2 8 95 135 ొ æ ₹ ESA-1-11050URCE/ HMD DETECTOR DYNAMIC RANGE 25 £ \$ 3 79 ⋷ EA-1-95 SOURCE/ ESA-2-95 DETECTOR DYMAMIC RANGE 书 33 80 9 104 2 ESA-1-110 SOURCE/ ESA-2-95 DETECTOR DYNAMIC RANGE 50 62 75 SEXTUPLER SOURCE/ ESA-2-95 DETECTOR DYNAMIC LANGE 75 ⋷ £ ESA-1-110 SOURCE/ ESA-2-110 DETECTOR DYNAMIC RANCE 25 70 48 3 120 52 90 * ESA-2-110 CONVERSION LOSS 37 30 43 3 9 42 *

Fig. 1.7.

* RESULTS IN THESE COMMINS HAVE BEEN MEASURED

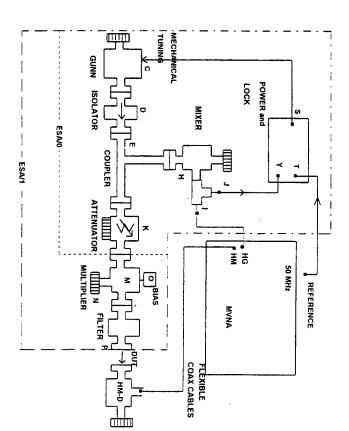
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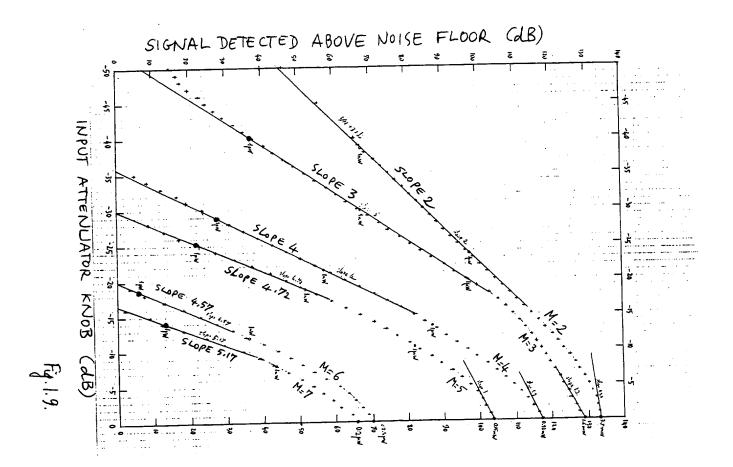
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TALLAHASSEE

ESA OPTIONS. RELEVANT PARAMETERS



F. 1.8.



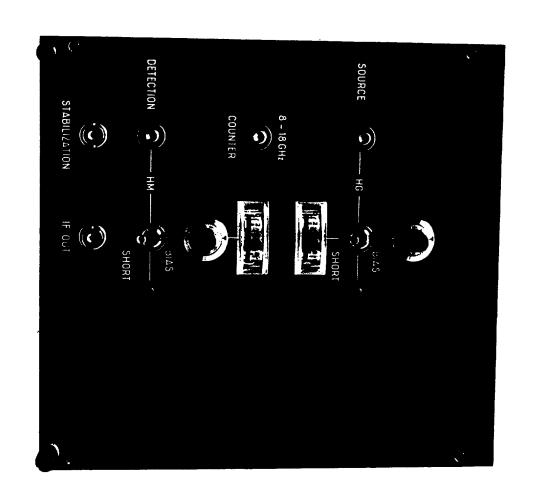


Fig. 1.10.

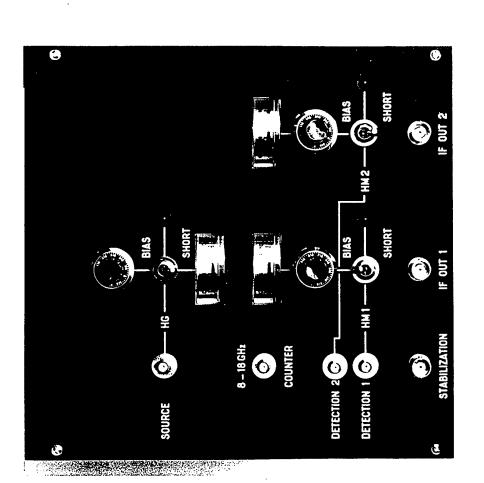
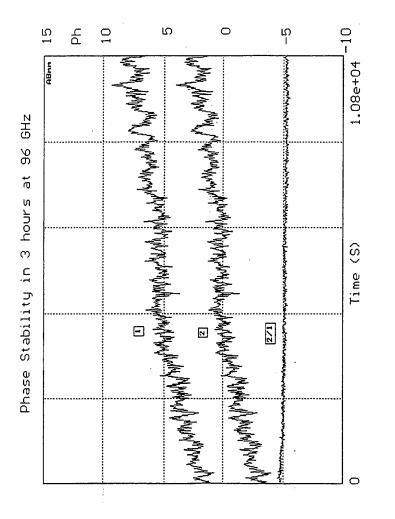


Fig. 1.11.



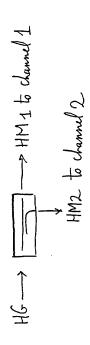
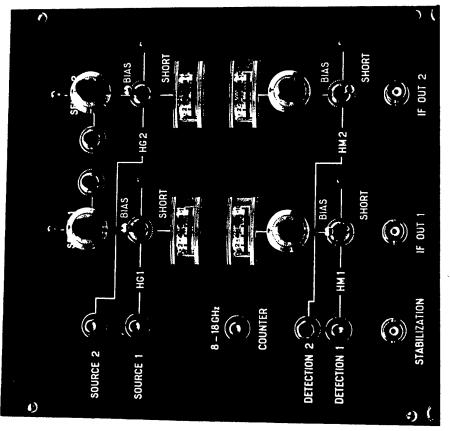
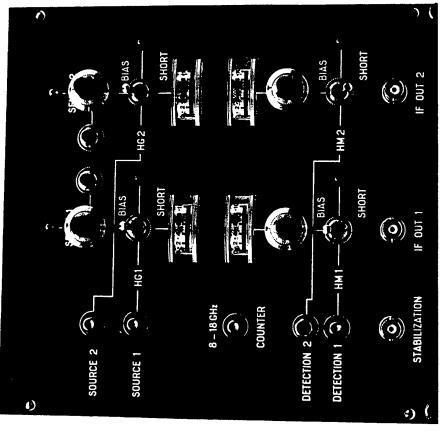


Fig. 1. 12.





Frequency (GHz)

-40 |

Dual Frequency independent behaviour

94.6 GHz

 30

dB 30

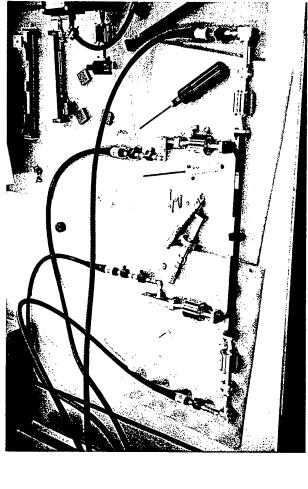
Dynamic Range in dual frequency sweep

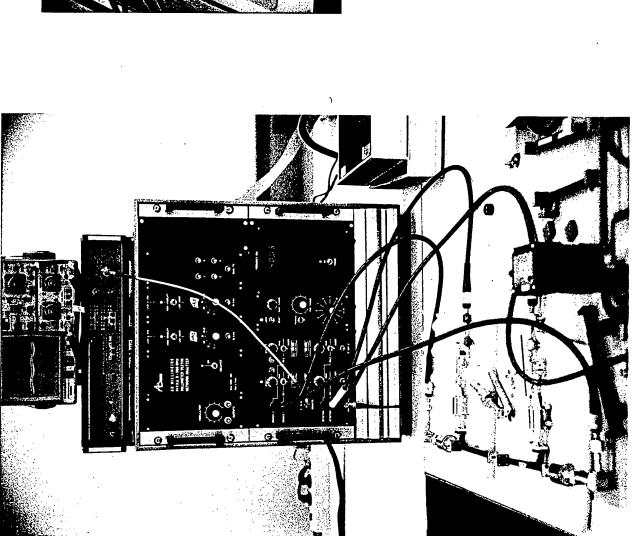
30, 375-36 GHz

dB 140

81-96 GHz

Time (S)





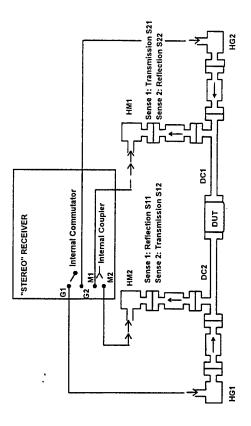
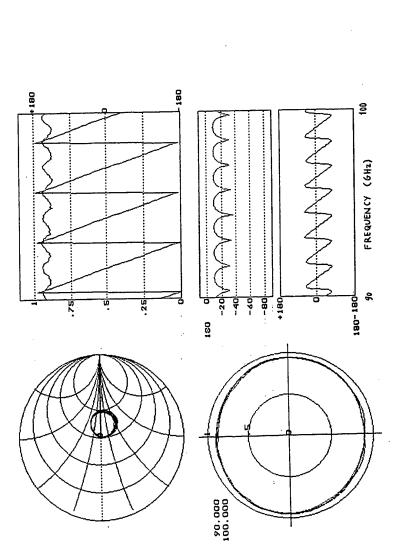
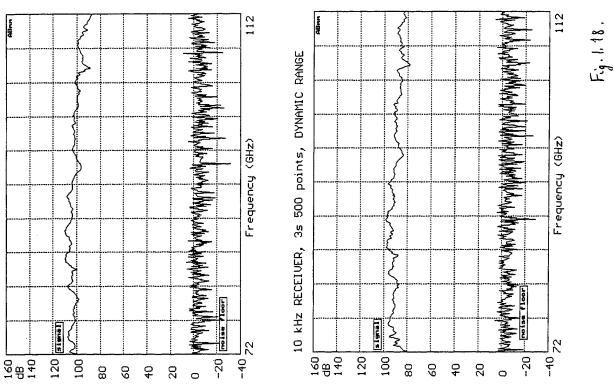


Fig. 1. 16.

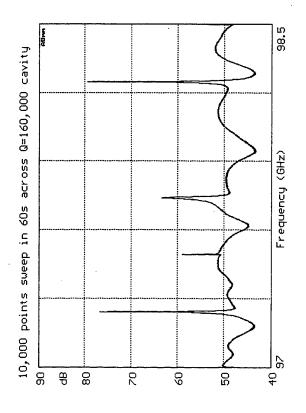
Fi. 1. 15







488 Hz RECEIVER, 30s 500 points, DYNAMIC RANGE



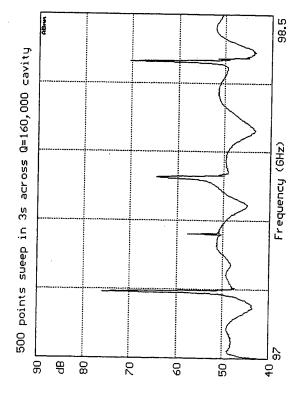


Fig. 1. 19.

Fig.II.1.

The size of the millimeter components can be small. In Fig.II.1 are shown, from top to bottom, four W-band (75-110 GHz, WR-10) components: a scalar horn, a Potter horn, an attenuator, a lens-horn antenna; at bottom is an E-band (60-90 GHz, WR-12) standard gain pyramidal horn. Vertical ruler is in cm. With such small items connected to the small MVNA millimeter heads, measuring antennas can be a favourite and easy use of the MVNA. Moreover, the large available dynamic range permits fast and accurate measurements.

Fig.II.2.

A typical antenna measurement setup is shown in Fig.II.2. On the left is the standing HG-D source for 143 GHz. On the right is the Micro-Controle Co rotating table which permits the azimuth angle variation through a step-by-step motor drive controlled by the standard MVNA software. The antenna under test at 143 GHz is attached to this table, and the flexibility of the HM-D coax cable (at right) allows +/-90° angular sweeps.

Fig.II.3.

With the scalar analyzer MSNA, good amplitude antenna pattern could be obtained with a very simple setup like in Fig.II.2, where the step-by-step motor was replaced by a synchronous motor making 1 turn/minute, i.e. -90°/+90° in 30 seconds. Fig.II.3. shows an exemple of such a scalar measurement observed at 50 GHz on a conical horn from Thomson-CSF.

Fig.II.4.

Scalar horns around 95 GHz (Fig.II.4, top) and 230 GHz (Fig.II.4, bottom) have been designed and produced by the Labo DEMIRM, Radioastronomy group of Paris-Meudon-ENS (M. Gheudin, G. Beaudin). The quality of the antenna pattern, measured with the MSNA, is extremely good, especially for the 95 GHz horn, where secondary lobes (if any!) appear to be below -45 dB (Fig.II.4., top).

Fig. 11.5.

The 230 GHz scalar horn of Fig.II.4, bottom, has been measured in more comfortable conditions, as shown in Fig.II.5, with the MVNA and an extension ESA-

Fig.II.6.

A Gaussian optics lens-antenna at 60 GHz, is made from a scalar horn feeding a dielectric lens of large aperture (around 10 cm). The aperture of the horn is at the focus of the lens. The antenna pattern as delivered by the factory (Fig.II.6., top) is not as good as the true antenna pattern as observed with the MSNA (Fig.II.6., hottom)

Fig.II.7.

With the same principle of a lens-horn antenna, a small 333 GHz Potter horn feeds a 35mm diameter teflon lens realized at DEMIRM (J-C Pernot). One can compare the E and H-planes antenna patterns of the horn alone, or associated with the lens. There is a dramatic narrowing of the beam, and a gain, along the axis, of the order of 17 dB (Fig.II.7, top). The dynamic range of the measurement is over 70 dB in the measurement conditions, as shown in Fig.II.7, bottom.

-ig.11.8.

The measurements which have been described above (Figs.II.3-7) are interesting. However none of them uses the phase information.

Now let us consider measurements which are not possible without observing the phase.

On a pair of smilar WR-10 Potter horns designed to work around 95 GHz, a vector measurement in a 70-110 GHz sweep gives a return below -22 dB (Fig.II.8, top and middle). The **Fourier transform FT** of these returns, gives similar responses for the two in the **time domain** (Fig.II.8, bottom).

Fig II 9

The time domain can be viewed as a **length domain**, the speed of light in the propagating medium being the scale coefficient. Thus the FT of return signals will give the positions of the mismatches as peaks. A non-destructive inside view of any propagating component, including antennas of course, can be realized. For a simpler visualization, the FT diagram can be represented at the geometrical scale of the component. Fig.1I.9, top, shows such a FT signal obtained from a 70-110 GHz return signal from a Potter horn. The main mismatch is occurring at about half-distance of its total length, where is the excitation of the two circular modes, after the long rectangular-circular transition. Fig.II.9, bottom, shows the same for a scalar horn, where the excitation of the circular mode is operated closer from the input flance.

Fig.II.10.

A conical horn can have a very low return (below -30 dB from 86 to 110 GHz for a WR-10 horn, see Fig.II.10, top). The association of a Fresnel lens attached to the horn aperture increases the return (which is around -20 dB from 86 to 110 GHz, see Fig.II.10, middle). The FT time (or distance) display permits to understand precisely the effects of the parasitic reflexions due to the lens. In Fig.II.10, bottom, the plane input surface (hidden) of the lens creates a mismatch which is 12 dB above the mismatch of the aperture of the horn without lens. The curved output surface of the lens (made from Fresnel steps) creates a mismatch which is 5 dB below that of the plane surface.

Fig.II.11.

Far from the emitting antenna, the wave can be viewed as spherical, coming from a point called **phase center**. The precise determination of the phase center is crucial in all alignments and optimizations for obtaining the best Gaussian beams. Indirect measurements, from scalar measurements, are long and not unambiguous, contrary to direct vector measurements. For this reason and for the rich FT possibilities in antenna characterization, **vector measurements are very much to be preferred to scalar measurements**. The phase center search setup comprises, among others, a lateral adjustment and a longitudinal adjustment (Fig.II.11). For fulfilling the far field conditions, the distance L between the source of typical aperture D, and the detection of the same aperture, must be:

 $L > 2D^2 / \lambda$. (II.1.)

Due to the large number of wavelength λ contained in the distance L, a small change in frequency may induce a very large change in the detected phase. For this reason, the antenna measurements will preferably be operated at a synthesized frequency (stabilization obtained from the EIP 575 (or 578) frequency counterstabilizer). Moreover, one can compensate for the large phase versus frequency dependence by adding distance in the coax cable going to the HM. About 1m of our centimeter coax cables compensates for 1.2m millimeter waves propagation in air. For that reason the MVNA must stand on the HG source side, and the long cable must be connected to the HM detector on the measured antenna side.

Fig.II.12.

The phase center search, operated with the appropriate setup (Fig.II.11), consists in finding firstly the "optical" plane of symmetry of the antenna (which can be different from the "geometrical" plane of symmetry). As soon as the rotation axis does not belong to the optical plane of symmetry, there is a global move, towards or backwards, of the measured antenna aperture versus the far emitting antenna. Therefore the phase increases, or decreases, with rotation. This symmetry determination is very sensitive on the phase, and not at all on the amplitude. Such a phase center search is operated in Fig.II. 12, at 285 GHz in the H-plane, by 0.2 mm lateral steps of a conical horn (from DEMIRM). The axis of rotation belongs to the plane of optical symmetry when the phase variation is horizontal around the zero azimuthal angle.

Fig.II.13.

The second step of the phase center search is operated in varying the longitudinal position of the antenna (Fig.II.11). Similarly to the same operation with the lateral position, but less sensitive (1 mm steps instead of 0.2 mm, respectively), one obtains the phase center position when the phase change with azimuth angle is flat, the curvature being up or down for the tested antenna too far, or too close (Fig.II.13, same conditions and same conical horn as in Fig.II.12).

Fig.II.14.

When measuring an antenna pattern versus azimuth angle, the Gaussian beam signature consists in observing a flat phase dependence, and a parabola for the amplitude when shown in log units (dB). Scalar horns (corrugated) are, most of the time, broad band devices. The Company Farran Ltd developped such a scalar horn for a meteorology satellite, where water vapour is to be characterized at the 183 GHz H2O line, and also around the line, by +/-8 GHz. Final tests were operated at AB Millimètre, where a disaster occured at the upper frequency 191 GHz. On Fig.II.14, one sees a good Gaussian profile at 175 & 183 GHz. The 191 GHz profile is not Gaussian: the phase is not flat, and the amplitude has not a parabolic shape. This horn was rejected.

ig.II.15.

A good scalar horn gives very similar antenna patterns at all polarizations (E & Hplanes). The only parameter changing with frequency is the beam width, which is narrowing with frequency, according to diffraction laws. Fig.II.15 shows the second scalar horn after redesign, from Farran Ltd. This horn, excellent, was accepted.

Fig. 11.16.

The measured phase profile of a non-Gaussian antenna can be used to design a dielectric lens, in view to correct the emitted phase curvature and to obtain a Gaussian profile. A conical horn antenna made by Thomson CSF Co (Fig.II.16, top) presents a beam which is not Gaussian: the amplitude is not a parabola (Fig.II.16, middle), and the phase is not flat (Fig.II.16, bottom). The lens profile reproduces the phase pattern around the axis. When the lens is attached to the horn aperture, the emitted phase is flat around the axis: the emitted beam is Gaussian (the amplitude has a parabolic shape), and the amplitude gain on the axis is 10 dB.

Fig.11.17.

Antenna measurements are very demanding in dynamic range. Submillimeter waves measurements will be performed with the help of extension ESA. The setup for a 380 GHz antenna pattern characterization, including an ESA-1 source (Fig.II.17) is quite similar, on the detection side, to the one used for 143 GHz measurement (Fig.II.2).

Fig.II.1

In the submillimeter domain, Potter horns are much easier to build than scalar horns, since they do not require corrugations which are more and more difficult to machine with increasing frequencies (i.e. decreasing wavelength, i.e. demanding smaller and smaller corrugations). They are much more restricted in band than the scalar horns. When used, within a few percents, at the frequency for which they have been designed, they can present very low sidelobes and a good E and H-planes symmetry. Fig.II.18 shows the angular antenna pattern of a 380 GHz Potter horn made from Peter Zimmermann RPG, measured in the setup described Fig.II.17.

Fig.II.19.

Potter (also called dual-mode) horns create a beam which is the combination of two beams with opposite phase curvature. In the vicinity of the axis, the phase of the resulting beam is not flat, but stationary. This explains the low side lobes position. However, the beam is not exactly Gaussian. In Fig.II.19 is shown the detail of the H-plane antenna patern of the 380 GHz Potter horn of Fig.II.18. The amplitude does not show a parabolic profile. The opposite curvatures of the two modes are visible. The phase repeatability, of the order of 3 degrees, could be attributed to a mechanical repeatability of 6 micrometers.

Fig.11.20.

Millimeter waves correspond to small wavelength, allowing reduced size antennas which fit into missiles. Monopulse antennas are used for radar search and trak of targets. In such an antenna, one combines, by sum and difference, two beams. The sum gives a maximum on the axis, with a Gaussian shape and a flat phase dependence around the axis. The difference gives two beams apart from the axis, about zero amplitude on the axis, with a phase jump of 180°. Fig.II.20 shows amplitude (top) and phase (bottom) measured, in less than 30 seconds without any data averaging, on a very good monopulse antenna at 94 GHz.

Fia.11.21.

The antenna measurement facility at Matra Marconi Space, Toulouse, France, is equipped with MVNA-8-350 since 1991. A great number of vector antenna charaterizations could be operated in the millimeter range. Due to very accurate determinations, especially on the phase center, the necessary room for final geometry adjustments at the telescope focus could be reduced by an order of magnitude, which is very interesting in view of satellite radiometers. In Fig.II.21, top, is shown the measured MVNA+ESA signal amplitude stability during 15 hours, when temperature of the laboratory drops for about 2.5 °C, Fig.II.21, bottom.

D

Fig.II.22.

A telescope antenna has a single focus. However it is quite possible to use the same telescope for combined observations at different frequencies and polarizations, using beam splitters, dichroic filters, grid polarizers, etc. Such systems are particularly useful for increasing the efficiency of expensive satellite missions. The number of different frequencies can be as large as five (Matra-Marconi Space, in progress). In Fig.II.22 is shown the schematic diagram of a four-frequency telescope platform. The four frequencies: 63, 118, 184 and 205 GHz, are related to the molecular species to be observed: O2, H2O and O3. The reversed (from detector to source) optical path at 205 GHz (O3 frequency) is: the scalar horn, a parabolic mirror, a polarizer, an elliptic mirror, the dichroic filter d1, the dichroic filter d0.

16.11.23

The phase center precise determination is particularly necessary when the cylindric symmetry of the antenna is broken. This is the case for a scalar horn fed through a dichroic filter, due to the refraction of the incident beam across the filter finite thickness (see Fig.II.23).

Fig.II.24.

The angular vector antenna pattern observed from the scalar horn-dichroic mirror system can be extremely good, as soon as the rotation is operated around the true phase center. Fig.II.24, communicated by Matra-Marconi Space, shows such a nearly perfect Gaussian beam observed at 62.5 GHz on the E and H-planes of the horn-dichroic mirror of Fig.II.23. Circles and triangles are for the amplitude, in dB, of E and H-planes, respectively. Crosses and X are the phase, in degrees, for E and H-planes, respectively.

Fig. II. 25.

The copolar and crosspolar diagrams are obtained by data treatment after "azimuth" acquisition (horizontal rotation of the tested antenna) operated at different "roll" (roulis) angles (the tested antenna is rotated along its own axis), for a vertical polarization of the emitted wave at first, then for an horizontal polarization of the emitted wave. A perfect Gaussian beam gives, naturally, circles for a given intensity in the copolar diagram. Fig.II.25, communicated by Matra-Marconi Space, shows such a very good copolar diagram, obtained on the horn-dichroic filter of Fig.II.23 at 62.5 GHz. From the center at 0 dB and going to any external direction, one finds the circles at the levels -5, -10, -15, -20, -25 and -30 dB.

Fig.II.26

In Fig.II.26, communicated by Matra-Marconi Space, is shown the crosspolar diagram obtained at 62.5 GHz from the scalar horn-dichroic mirror of Fig.II.23. The comparison with Fig.II.25 leads to the good maximum crosspolar/copolar ration at 26.5 dB.

Fig.II.27.

The very complicated 205 GHz optical path described in Fig.II.22 gives a reasonably good antenna pattern, as measured in Fig.II.27 at Matra-Marconi Space. Same symbols as in Fig.II.24.

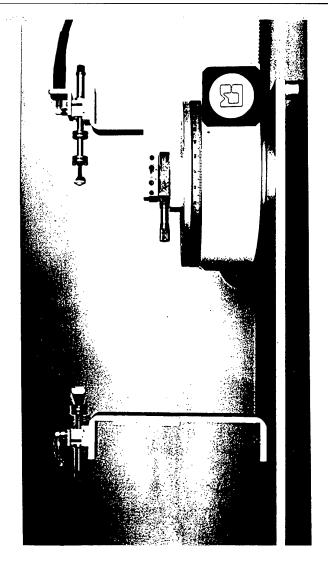
Fig.II.28.

The copolar diagram of a non-perfectly Gaussian beam deviates from circles. In Fig.II.28, communicated from Matra-Marconi Space, is shown the copolar diagram of the 205 GHz channel of Fig.II.22. From the center at 0 dB, one finds the curves at 5, -10, -15, -20, -25 and -30 dB, respectively.

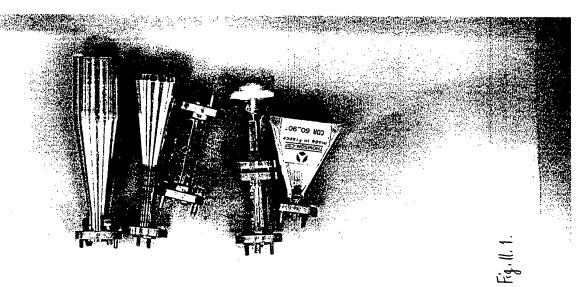
Fig.II.29.

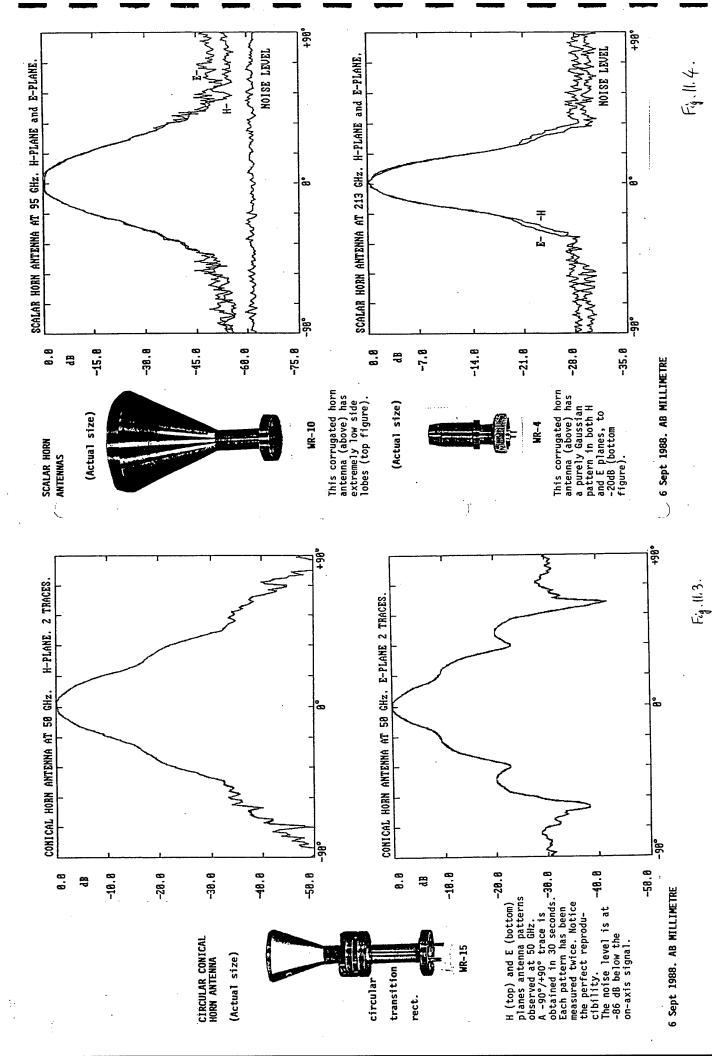
The crosspolar diagram corresponding to the copolar diagram of Fig.II.28 is shown in Fig.II.29, from Matra-Marconi Space. The comparison of the two gives still a good maximum for the ratio crosspolar/copolar at -25 dB.

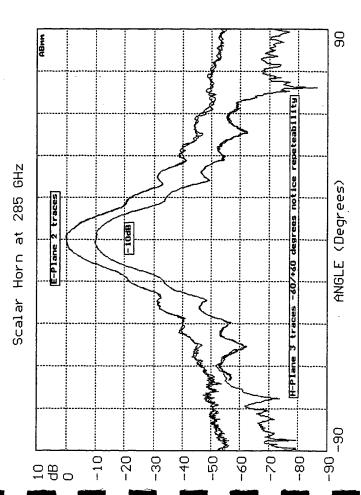
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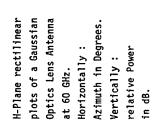








AB MILLIMETRE MSNA OFFERS THE EASIEST AND MOST ACCURATE WAY OF MEASURING ANTENNA PATTERNS

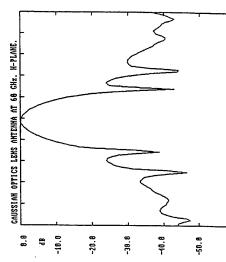


9 -13

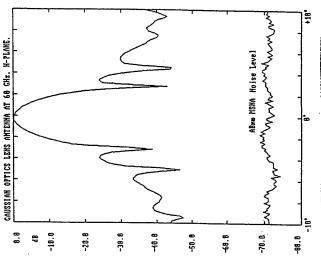
8 s

-20 -25 -30

As provided by the Factory.. Top :



As done in 20 AB MILLIMETRE seconds with Bottom:



Fà,11.6.



H without Lens

w j

-20

-25

-30

-35

ш

ANGLE (Degrees)

-33

-50

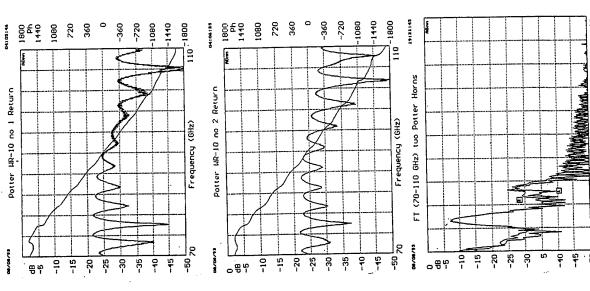
-40 -45

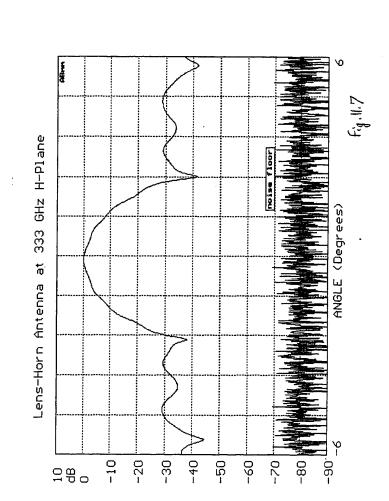
6HZ

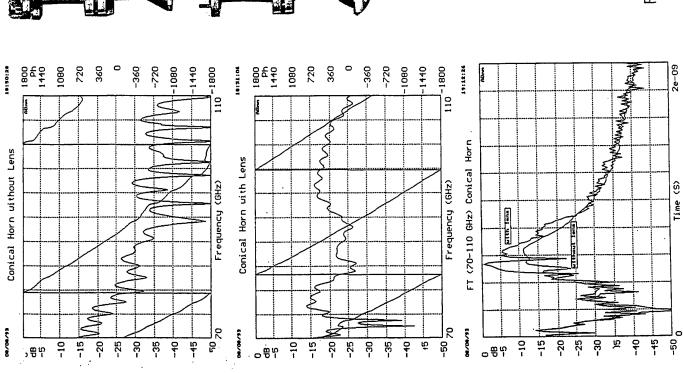
333

Potter Horn without/with 35mm Lens at

0 9 GB 12







70-110 GHz FT

8P

PoTTER

HORN

79-110 GHZ FT

Fig.11. 10.

Fig.11.9.

SCALAR HORN

0.1 0.2

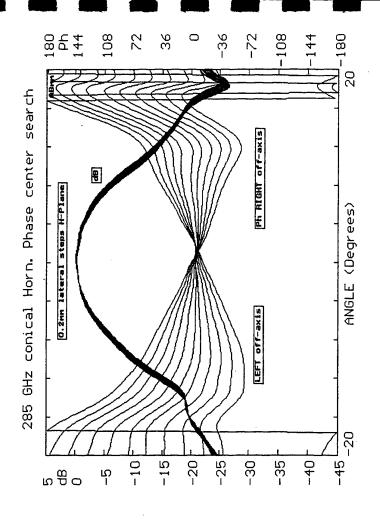
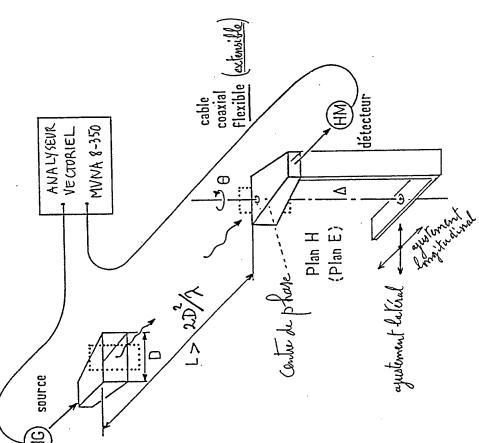
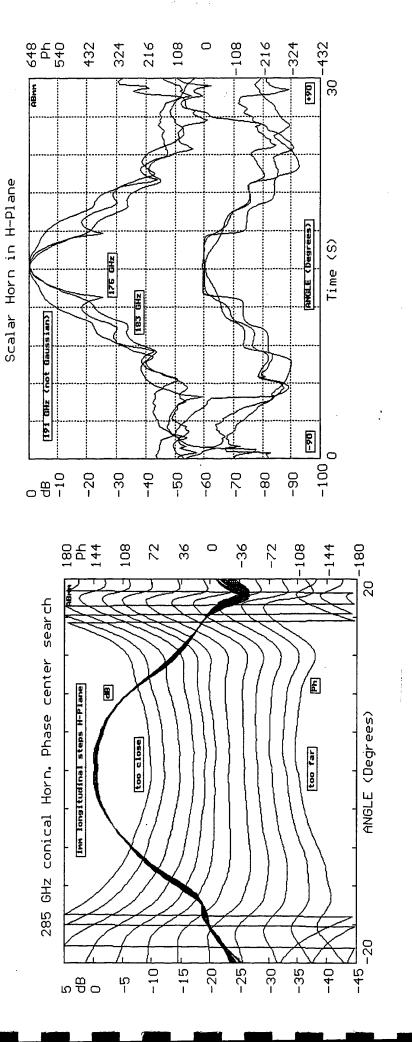


Fig. 11. 12.



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Fg.11.13.



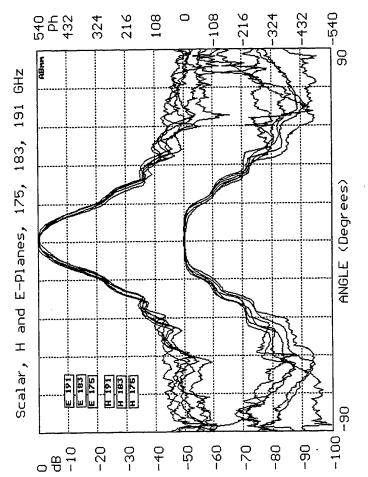


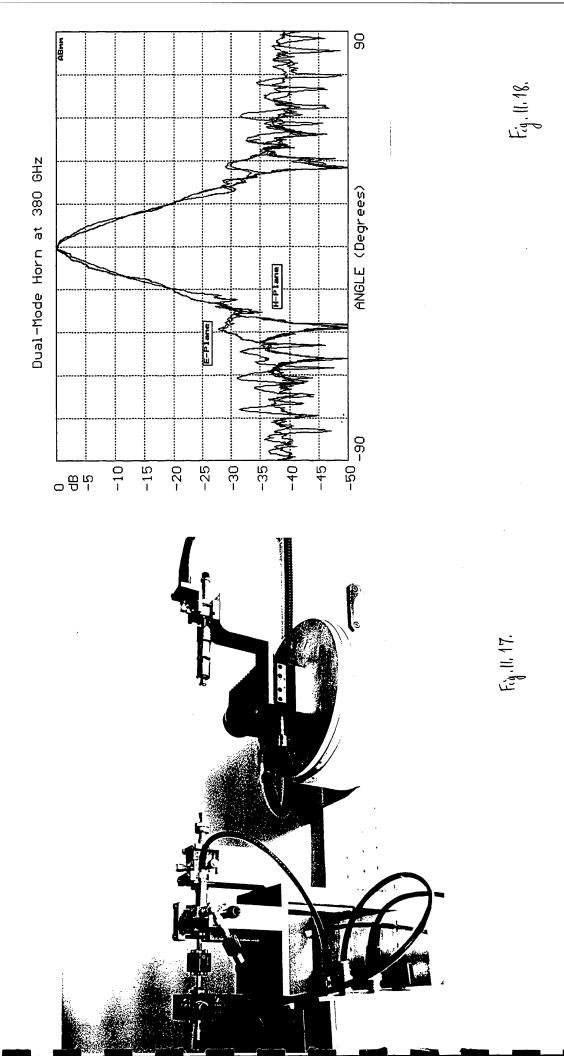
90 -450 -90 -270 450 Ph 360 270 180 -180 143 GHz H-Plane Horn, with or without Lens dB without Lens dB with Lens. Notice repeatability Ph without Lens (not Gaussian) Ph with Lens (Gaussian) ANGLE (Degrees) -90 -40 -60 -80 -90 -10 -30 -50 -20 080

90

Fig. 11.15.

Fig. 11. 16.





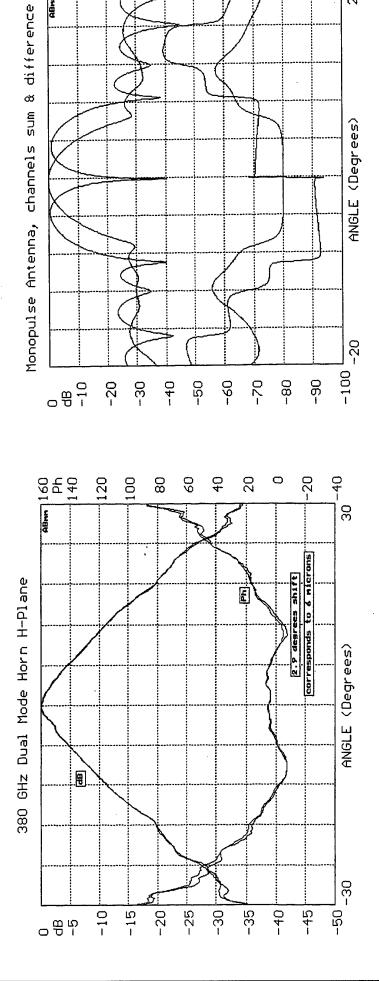
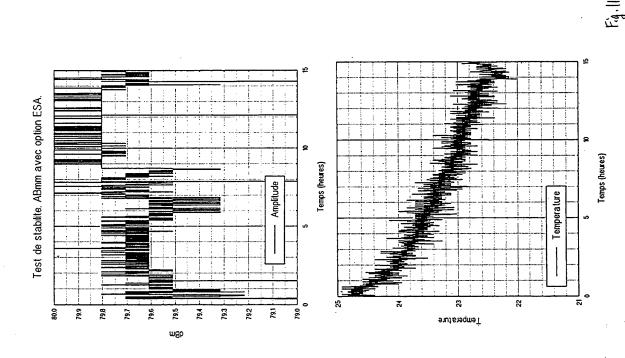




Fig. 11.19.

20 -180

-90

Ph 

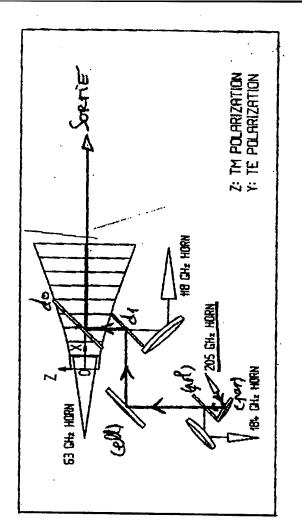
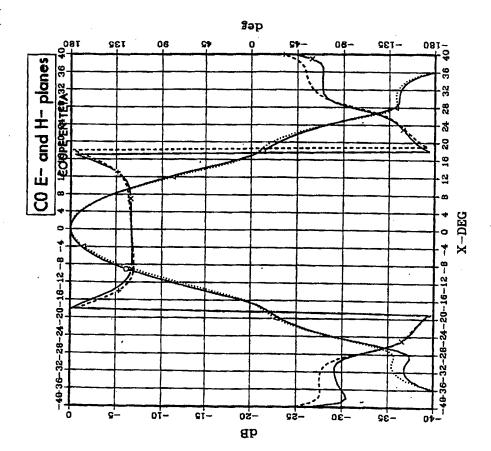


Fig. 11,22



Dichroic quartz plate at 45°

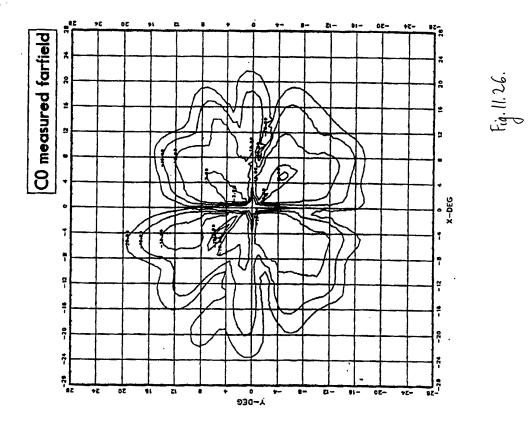
Optical axis

Horn axis

φ7λ Horn aperture diameter

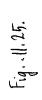
Phase center of the horn alone





7-0EG

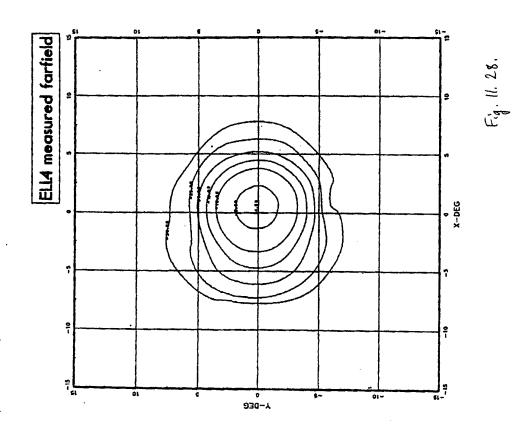
CO measured farfield

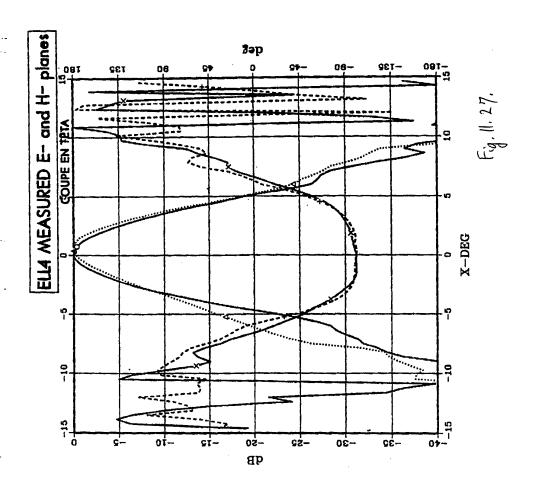


X-DEG

-30

21- 91-





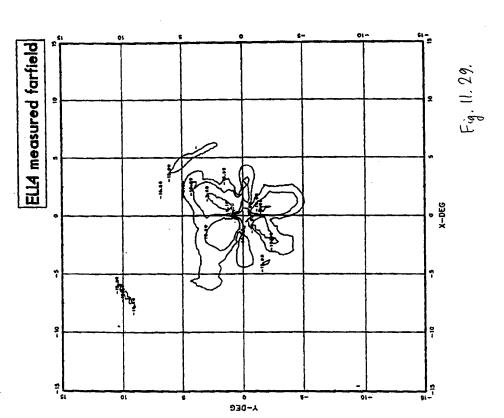


Fig.III.1.

With the vector analyzer MVNA 8-350, the transmission between the two horns (or two horns refocussed by two, or four, lenses) is firstly calibrated. Then one introduces the sample between the horns, and measures the change in amplitude and phase. For dielectric materials, and when eliminating the standing waves effects, the change in phase can give the permittivity ε , and the change in amplitude the loss tangent tanδ.

The change in phase ∆∮ (in degrees) due to the introduction of the slab of thickness e and refractive index n, instead of the same thickness of air of refractive index close to 1, can be predicted, with an integer number of turns k:

$$(n-1)e/\lambda = (\Delta\phi/360) + k$$
 (III.1

the refractive index n is related to the permittivity ϵ^t by the law:

When the dielectric material is relatively lossy (practically loss tangent tan δ >0.001), measurement of the tan δ is extracted from the observed decay of transmission α (in dB/cm), through the formula:

$$tan\delta = 1.1 \alpha (dB/cm)/nF(GHz)$$
 (III.3.

Fig.III.1, top, shows a rectangular plot, bottom a polar plot, with the amplitude in dB as the radius, and the detected phase as the angle, when introducing a bevelled Plexiglas sample between horns at 186 GHz. Both variations (amplitude drop in dB, phase) are linear with the actual thickness of Plexiglas, explaining the observed spiral shape. There is 13 phase turns (k=13, $\Delta \phi = 0$), and the drop is 6 dB for 35 mm, so that one obtains the good values of permittivity $\varepsilon = 2.59$, and loss tan $\delta = 0.006$.

Fig.111.2.

Most of the samples to be measured have a simple plane-parallel shape, and the observed phase rotation does not give the integer number of turns. Then, several frequency points, or a frequency sweep, can give a complete determination of phase variation. The measurement in Fig. III.2. is performed with two rather poor quality E-Band (60-90 GHz) pyramidal horns facing each other. After a first frequency sweep to take the intrumental response, a 20mm thick fused quartz Tokamak window has been introduced at a given position between the horns. Then, the position of this sample has been changed before a second measurement. The superimposed two traces in Fig.6 show mostly the standing waves between the sample and the horns, which look like noise, but which are quite reproducible. (Measurement realized at Cadarache - Tore-Supra reactor, thanks to G. Berger-By and M. Paume).

Fig.III.3.

Fig.III.3, top, presents the Fourier Transform FT of the transmitted signal with the dielectric sample in the 1st position of Fig.II.2, and Fig.III.3, bottom, the FT of the 2nd position.

Fig.III.4.

In Fig.III.4, top, are simply superimposed the FT signals (of Fig.III.3) corresponding to the two sample positions. The first two peaks are not changed: they correspond to the time necessary for the wave to cross the sample. In Fig.III.4, bottom, are superimposed these signals, after having moved the second versus the first by an offset corresponding to the change in position of the sample, between the two recordings of Fig.III.2. The peaks due to the reflexions between the sample and the fixed obstacles, such as the horns, are now superimposed. The FT filtering will be operated by cutting these contributions.

Fig. 111.5.

Fig. II. 5. is the same as Fig. III.2, after filtering the spurious standing waves effects on the Fourier transform as indicated above. One clearly sees the ondulations due to standing waves inside the sample. The phase evolution gives ε=3.802, and the loss is very small since the transmission maxima cannot be distinguished from 0dB (measurements in quasi-optical open cavity give tanδ=0.0004). Since the quartz slab sample is a low-loss material with a rather high permittivity, its acts as a Fabry-Pérot resonator, showing oscillations in amplitude with a period ΔF, according to the law:

The oscillations period (Eq.4) gives an approximate value of ϵ '. However it is the observed phase variation which gives the most accurate ϵ ' determination (by Eqs.1-

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-ia.III.6.

Standing waves problems and FT filtering solutions can also be observed in reflexion measurements. In Fig. III.6, top, is shown the signal amplitude reflected from a sapphire (dielectric constants ε'=9.40, tanδ<0.001) slab 9.97 mm thick, before and after filtering. Fig.III.6, bottom, is the polar plot, where the filtered signal is shifted by 180° for clarity.

Fig.III.7.

Transmission and reflexion amplitudes observed at the same time are varying in opposite directions, like it is observed with a 9.97 mm thick sapphire sample in Fig.III.7 (top: in dB, bottom: linear). The observed transmission minima correspond to maxima in reflection, with a maximum reflection amplitude coefficient r such as:

 $r = (\epsilon'-1)/(\epsilon'+1)$ (III.5.) (III.5.) (r=0.8=-1.86 dB for ϵ' =9.40 in sapphire). The corresponding minimum amplitude transmission coefficient t can be deduced from conservation power law: $r^2 + t^2 = 1$ (III.6.)

(t=0.6=-4.59 dB for sapphire).

Fig.III.8

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Fig.III.8. shows the polar plot of Fig.III.7. Reflexion signal describes a big circle R (due to full interference between multiple reflections). Transmission signal T decribes a cycloid. This clover-shape curve is the vector sum of the unity circle (transmission through the optical thickness ne of the sample slab without noticeable loss) with the transmission interference resonance circle, which is also shown (small circle "T-lin Ph" at right, obtained by substracting the linear variation of the phase in T).

.e.≡.e.

Transmission signal is enough for characterizing dielectric materials. Fig.III.9 shows the transmitted signal of Fig.III.7, with the actual phase "Ph" (declining trace), and the deviation of the actual phase from linear decrease ("Ph-Linear" trace around zero degree, corresponding to the small circle "T-lin Ph" in Fig.III.8). The actual phase exactly coincides with the purely linear variation, at the frequencies Fk where the transmission is maximum:

or at the frequencies Fk' where it is minimum: $Fk' = (2k'+1)c/4ne \quad k' \text{ integer}$ (III.8.)

k integer

Fk = kc/2ne

FK = (ZK+1)c/4ne K integer (III.8.)
The best frequencies for obtaining the permittivity ε' from the simple linear phase variation will be at the frequencies Fk and FK. The best frequencies for the loss are only at the values Fk (where the there is no standing waves inside the sample), the values at Fk' being the worst, due to maximum standing waves effects across the sample.

Fig.III.10.

By the single path transmission technique between horns as described above, materials which are not too much transparent will be easy to characterize. Fig. III.10 shows the transmitted signals observed through 5.06, 9.91, 19.96 mm thick PVC polymer samples (PolyVinylChloride, ε'=2.825, tanδ=0.01).

Fig.III.11.

With a 20.95 mm thick epoxy sample (Araldite) which is rather lossy, the standing waves oscillations are damped, so that the dielectric determination is fast and accurate (Fig.III.11, transmission and reflexion, top rectangular plot, bottom polar plot. One obtains from the measured transmitted Phase variation ε'=2.90, and from the amplitude drop tanδ=0.02).

 α

Most of our transmission measurements in the 70-100 GHz interval have been realized with a two-lens setup, the distance between the lenses being 200 mm, each lens having 100 mm focus. The source scalar horn aperture is placed at 200 mm from the first lens, the aperture of the detector horn at 200 mm after the second lens. After calibration of the instrument, the sample is inserted at mid-distance between the lenses. This setup is not free from standing waves effects, as it can be seen from data obtained at the European Microwave Conference, 5-8th September 1994. Fig. III. 12, top, shows observed transmission, without filtering, through 9.97 mm sapphire (compare to Fig. III. 8) and through 20.95 mm Araldite (compare to Fig. III. 11, bottom). A substantial reduction of these standing waves is obtained when inserting attenuators between the horns and the lenses (Fig. III. 12, bottom), total attenuation

Fig.III.13.

As observed above in a frequency sweep, standing waves give pig's tail shapes to the data. Periodic variation with position may also be seen at a fixed frequency, when moving the sample. The standing waves effects will be minimized at the frequencies according to Eq.III.7. Thus, a longitudinal move of the sample along the common axis xx' of the lenses would not induce any change to the measurement. On the contrary, standing waves effects are maximized at fixed frequencies according to Eq.III.8. A series of measurements have been performed, with the two-lens setup equipped with two attenuators (as in Fig.III.12, bottom) onto four dielectric samples moved along the xx' axis. Plexiglas thickness 3 mm, Araldite 20.95 mm, Teflon 10 mm, Sapphire 1.91 mm. For each sample, two frequencies have been used, the "best" (Eq.III.7) and the "worst" (Eq.III.8). Results are shown on Fig.III.13, where the "best" frequencies ("g" is for GHz) give small dots and accurate measurements, and "worst" frequencies give ellipses.

Fig.III.14.

The lenses of the 70-110 GHz setup do not have any surface treatment. They can be used at any frequency. Thus, the two-lenses setup can be used at submillimeter wavelengths. Scalar W-band horns are replaced by Potter horns, for instance at 475 GHz. Standing waves effects are observed at the 475 GHz fixed frequency, and can be damped by the attenuators. On Fig. III.14 are shown the observed signals versus the position of a 1.91 mm thick sapphire sample along the xx' axis. Top: amplitude in 4B, bottom, polar plane, where 10V means amplitude unity. Without any attenuator ("no"), the standing wave pattern ("banana shape") results in the sum of the standing wave on the source Submillimeter Harmonic Generator "shg" side (large circle), and on the detector Submillimeter Harmonic Mixer "shm" side (large eilipse). Single side standing waves effects are also observed separately, each one with an attenuator on the opposite side. With the two attenuators ("2"), the measurement is reduced to a single point, Fig. III. 14, top.

Fig.III.15.

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Standing waves spirals are observed with the two-lens setup, used in a 474.5-475.5 GHz frequency sweep without attenuator (Fig.III.15). Good measurements are obtained with attenuators, on sapphire (9.95 mm in a, 1.91 mm in b), Araldite (0.93 mm in c), Teflon (10 mm in d), Plexiglas (3 mm in e).

Fig.III.16.

The Gunn extensions of the analyzer do not allow computer controlled large frequency sweeps, since the electronic tunability of the Gunns is of the order of +/100 MHz. A large submillimeter sweep, like 469-479 GHz, will be made in several steps, mechanically retuning the Gunns between steps. At such high frequencies, the losses into sapplire are large enough to be measured from simple transmission experiments, tan\$=0.0008. Damping of the standing waves by attenuators is quite necessary. As shown in Fig.1II.16, large spiral (sweep versus frequency) and an ellipse (sweep versus position, at fixed 473 GHz) are visible when no attenuator is used. With the attenuators, the clover-shape curve is obtained. The losses into sapphire are large enough to be measured from this simple transmission experiment, tan\$=0.0008 at 475 GHz.

Fig.III.17.

The transmission through samples can be summarized by the polar plot of the results. In Fig.III.17, the dots, or lines (when the sample is thick enough) are given for 13 samples observed with the two-lens, two-attenuator setup, in a 283.55-284.15 GHz sweep.

Fig.111.18.

The Fig.III.18 shows results similar as in Fig.III.17, with a 473.4-474.4 GHz sweep.

Fig.III.19.

The Fig.III.20 shows results obtained in a 567.3-568.3 GHz sweep. Even with two attenuators, the standing waves are not completely damped, and the measurement accuracy is diminished.

Fig.111.20.

Measurements on polymers like araldite, plexiglas, nylon, in the millimeter and submillimeter, show practically constant values of ϵ ' and tan δ in the interval 18-190 GHz. Then, in the 190-760 GHz interval, are observed (see Fig.III.17-19) a very strong dependence of loss (which increases) and a slight dependence of permittivity (which decreases) on the frequency. In Fig.III.20 are shown the damping and the phase change (taken here upwards for clarity) of the microwave across a 10.95 mm thick sample of nylon The absorption strongly deviates from the extrapolation of its values observed in a 70-110 GHz sweep, for which the loss is tan δ =0.0145. It is only above 400 GHz that the phase rotation significantly deviates from the extrapolation from its values observed in the 70-110 GHz range, where one observes a constant permittivity ϵ =3.066.

Fig.III.21.

Instead of avoiding the standing waves effects, one can characterize low-loss (tanà <0.01) dielectric materials in controlled standing waves devices such as the open Fabry-Pérot cavity. Then, there are many back-and-forth crossings of the microwave through the sample, and perturbation effects, like absorption, are enhanced. In Fig.III.21 are shown the resonances observed by transmission in such a cavity tuned close to 478.5 GHz, empty (top left), or loaded with a 10 mm thick Teflon sample (bottom center). The resonance fits give ε =2.064 from the change in resonance position, and tanà=0.001 from the broadening.

Fig.III.22.

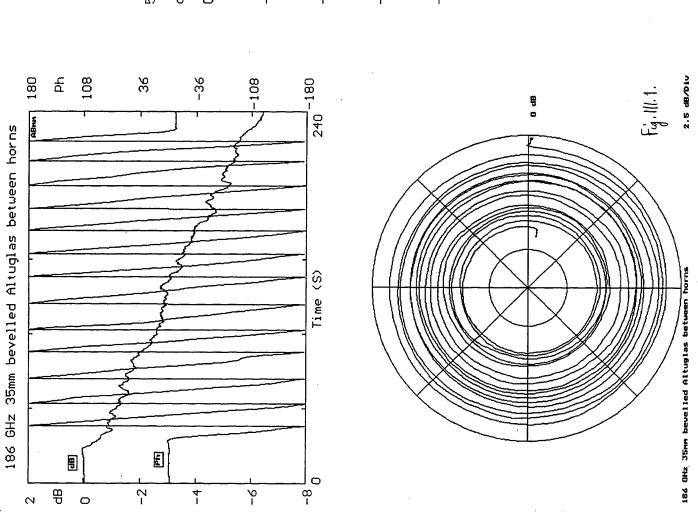
A whispering gallery mode can be excited into a resonant structure (a sphere, a cylinder, etc.) via the evanescent wave emitted from a total reflexion prism. A prism with a right angle at the summit, and 45° at the other angles, cannot be made from teflon, where n= $\sqrt{\epsilon}$ = $\sqrt{2}$.06=1.44, since the total reflexion angle i = arcsin(1/n) = 44° will be too close to 45°. On the contrary, Plexiglas, with ϵ =2.60, will give i=38°, which is fine. A very elegant way of obtaining the loss of a dielectric will be to measure the intrinsic quality factor Qo of a cavity entirely made from this dielectric, such as a whispering gallery mode cavity. One has simply:

$tan\delta = 1/Qo$.

Fig.III.22, top, shows the amplitude transmitted through the total reflexion prism, when varying the coupling to a cylindrical Rexolite slab (i.e. simply varying the distance from the prism side to the cylinder side). The critical coupling position corresponds to a big amplitude dip. On Fig.III.22, bottom, the corresponding phase variations split into two families: undercoupled, and overcoupled, with a brutal phase step at the critical coupling. These measurements have been performed during the "Hyper '92" exhibition, Paris, January 1992.

Fig.III.23.

The polar plot of the resonances shown in Fig.III.22 is extremely clear: the critical coupling trace contains the origin. Overcoupled resonances are circles with the origin inside, and undercoupled outside. The measured quality factor Ω increases with decreasing the coupling (there is less and less coupling loss). The outermost circle corresponds to the intrinsic quality factor Qo=830, leading to the rexolite loss value tanδ=0.0012, exactly similar to the loss measured in a cavity..



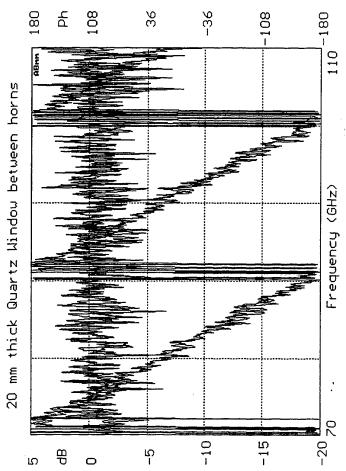
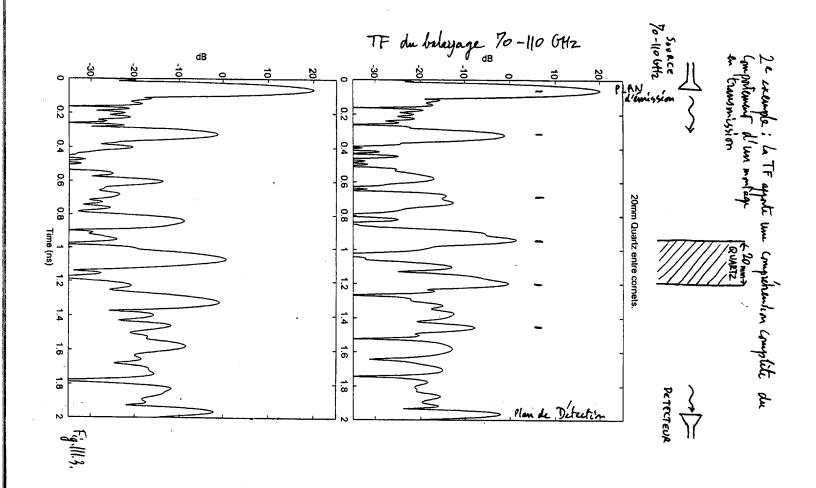
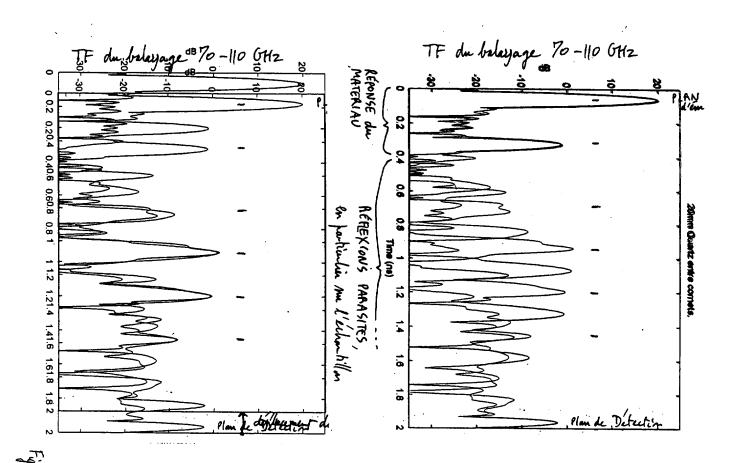


Fig. 111.2.





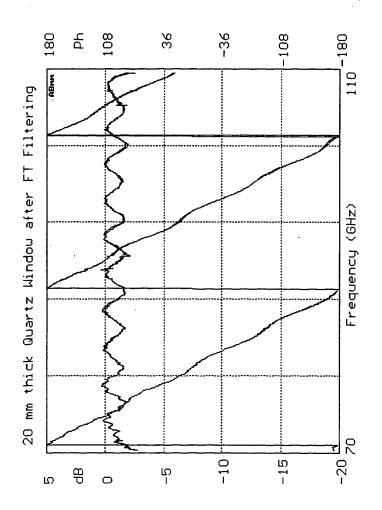
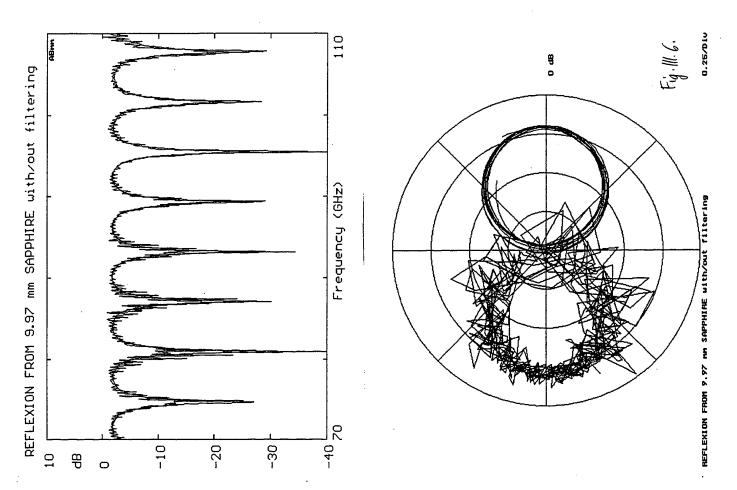
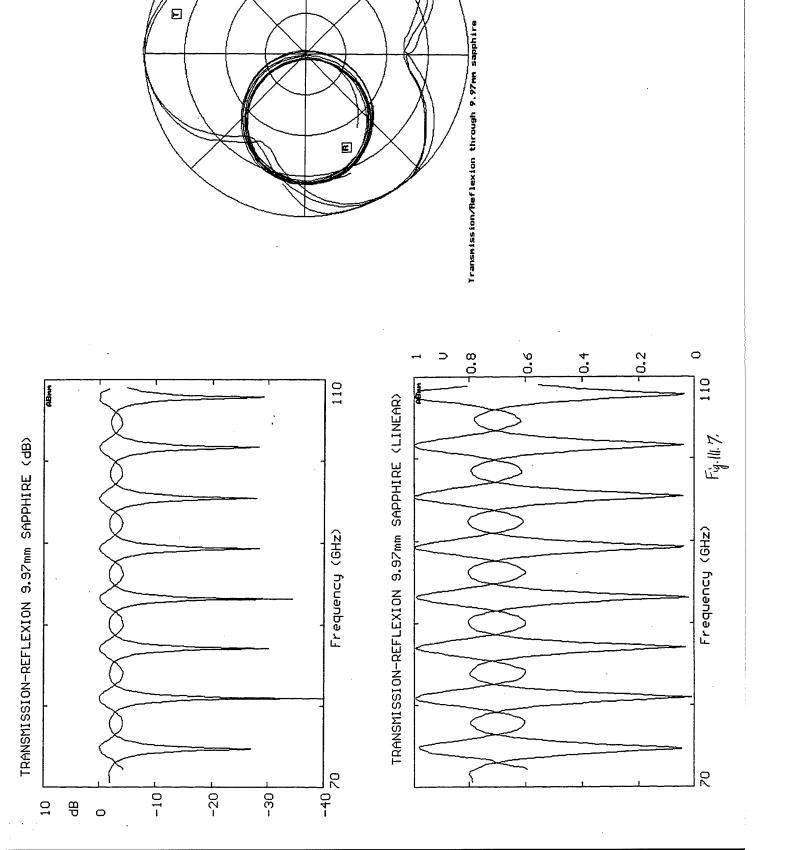


Fig.111.5.





Feb. 111.8.

2.5 v/Div

10 U

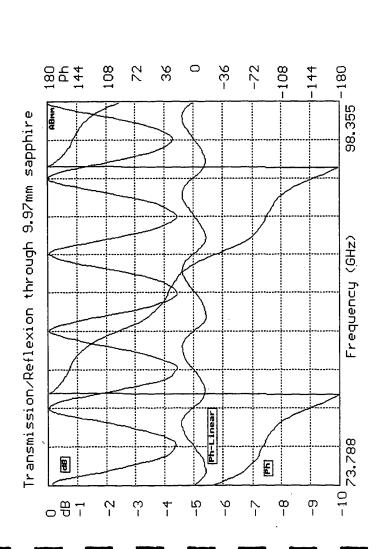
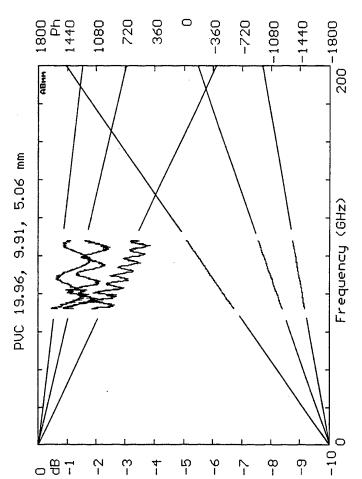
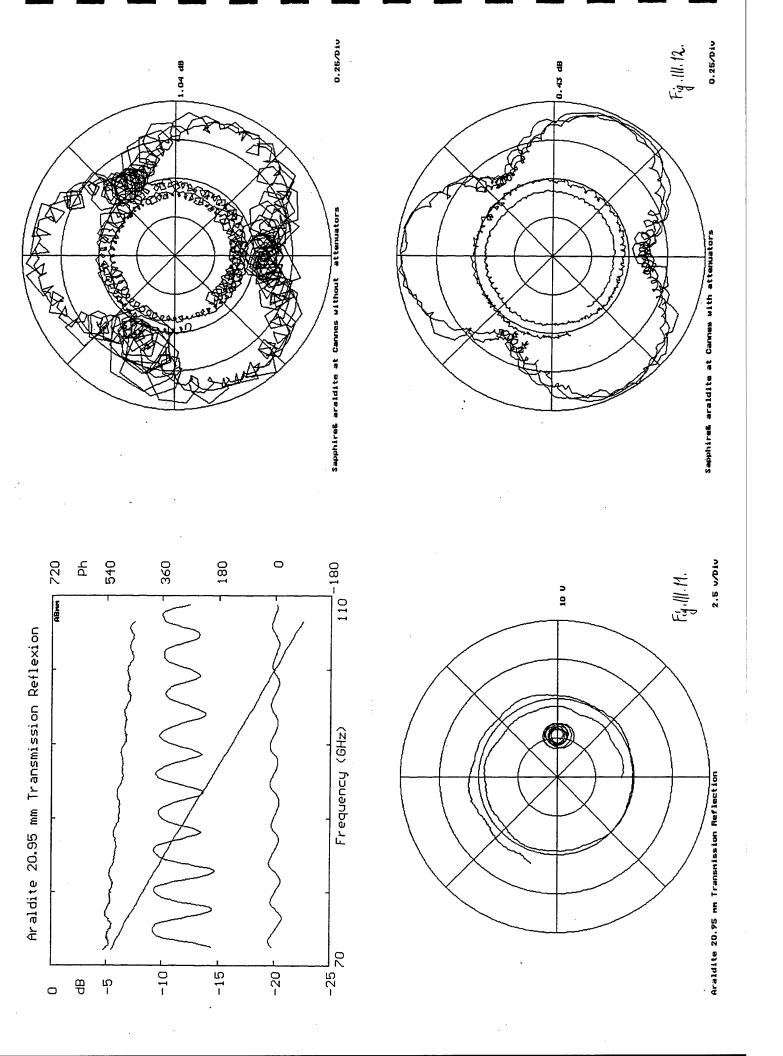
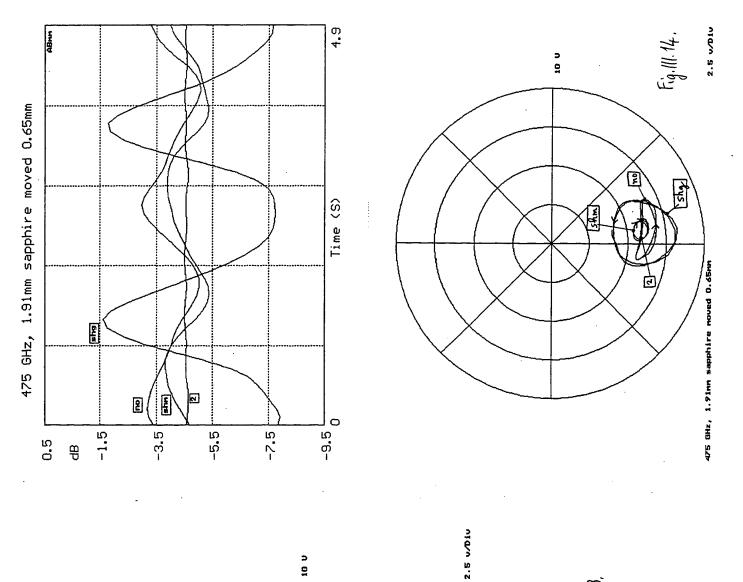


Fig. 111. 9,







tef10 88.833g

2-lens no max & min transmission us x sweep

sa2 1039

tef10 94.06g

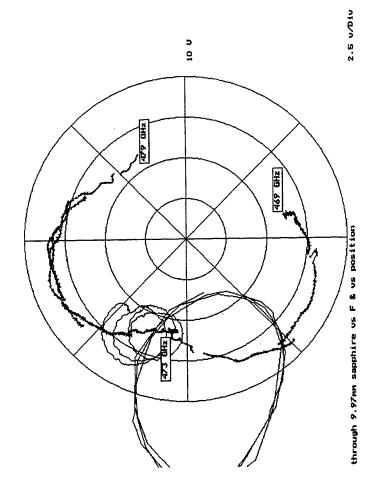
ara20.95 88.819g

ara20.95 90.6649

10 U

PIX3 104. 1038

plexi3 90.9459





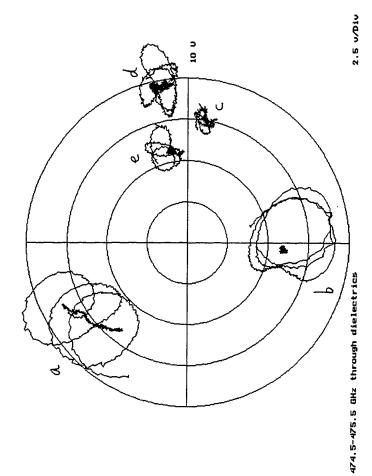
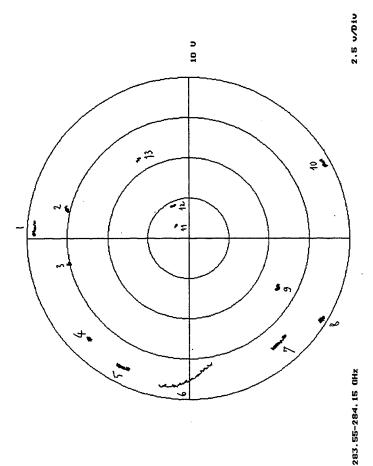


Fig. 111.15.



Hard screen copy issued on 01/06/96 at 22:07:16

List of printed registers

A: PRODIZEL MSN 01/05/94 21:14:17n1 array/lin 6

A: PRODIZEL MSN 01/05/94 21:14:17n1 array/lin 6

A: PRODIZEL MSN 01/05/94 21:20:21 belto 7

A: PRODIZEL MSN 01/05/94 21:20:14 pix 7

A: PRODIZEL MSN 01/05/94 21:20:10 rexio 7

A: PRODIZEL MSN 01/05/94 21:20:10 pix 13:31

A: PRODIZEL MSN 01/05/94 21:20:21 pix 13:31

A: PRODIZEL MSN 01/05/94 21:20:21 pix 13:31

A: PRODIZEL MSN 01/05/94 21:20:21 pix 13:31

A: PRODIZEL MSN 01/05/94 21:20:31 pix 13:31

Hard screen copy issued on 01/06/96 at 18:38:08

Fig. 111. 18.

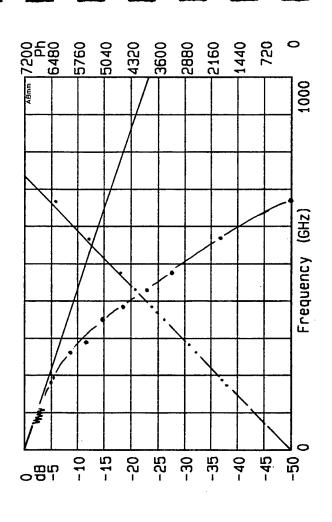
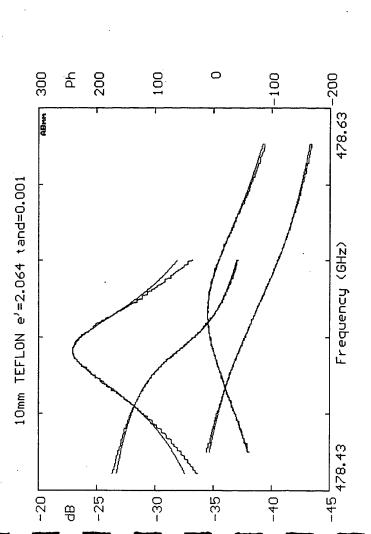


Fig. 111.20.

18:30:08 ter15 18:22:24 hi2pl sap corr 18:20:44 hi2plax sap 10 u	2.5 will
18:24:00 sa2 18:24:00 rex15 18:24:00 sa2 18:26:43 tef10 18:26:43 t	### ### ### #### #####################



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27.6 -100

Frequency (GHz)

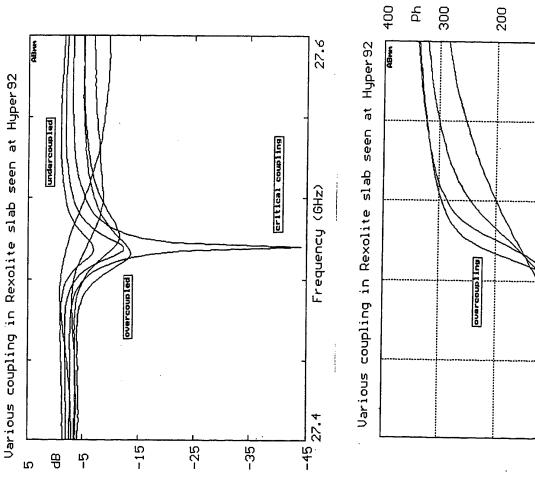
critical coupling

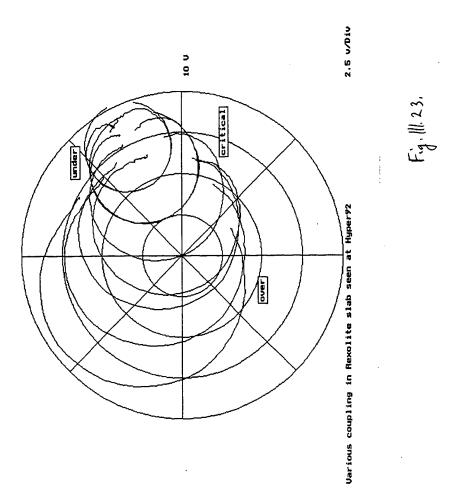
Fig.111.22,

100

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LIGHTWAVE/TERAHERTZ INTERACTION

AN OVERVIEW OF THE FIELD

THEME # 5

NATO ADVANCED STUDY INSTITUTE

July 9, 10

PROFESSOR HAROLD FETTERMAN

IICIA

LIGHTWAVE/TERAHERTZ INTERACTION

- * INTRODUCTION
- * TESTING USING SWITCHES
- * GENERATION USING PICO & FEMTOSECOND SOURCES
- * DIFFERENCE FREQUENCY MIXING
- * OTHER PROCESSES
- * NEW MATERIALS

EXAMPLES OF POTENTIAL TERAHERTZ SYSTEMS USING OPTICAL APPROACHES

- * OPTOELECTRONIC OSCILLATORS
- * OPTICALLY CONTROLLED PHASED ARRAYS
- * OPTICALLY CONTROLLED PHASE CONJUGATION
- * CONCLUSION

ADVANTAGES OF USING LIGHT

FOR TERAHERTZ SIGNALS

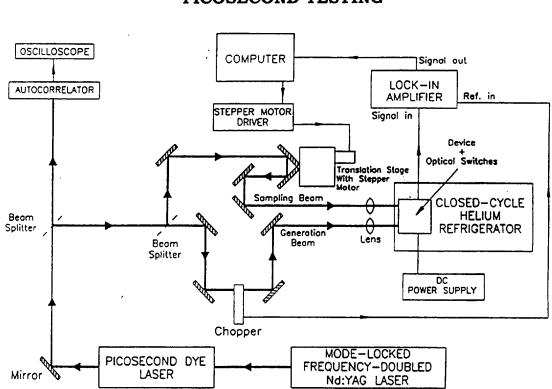
* High Laser Powers

* Natural For Transmission

* Narrow, Stable Laser Lines

* Advanced Optical Components

PICOSECOND TESTING

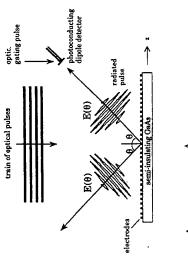


* Unique Systems Are Now Feasible

* Compact Solid State Implementations

* Pico & Femto Sources

PHOTOCONDUCTING ANTENNA ARRAY



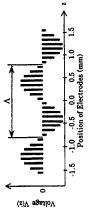


Fig. 1. Setup for the generation of an electrically steerable submillimeter wave beam. The array electrodes are sinusoidally biased with respect to their position, as shown. The array is illuminated with a train of optical pulses in order to generate quasi-sinusoidal radiation.

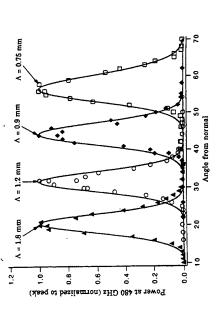


Fig. 8. Power at 480 GHz as a function of detector angle for several bias periods $(\Lambda_{\rm bias})$. Measurements were taken in transmission with the fiber-fed detector approximately 4.5 cm from the array. Solid lines show the theoretical fit, assuming an optical beam width of 6 mm (Gaussian).

LOW TEMPERATURE GaAs

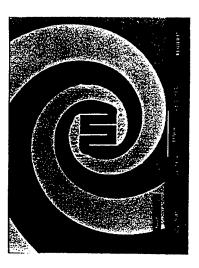


FIG. 1. Scanning electron micrograph of electrode region and first turn of spiral antenna for $8\times 8~\mu m$ photomixer (mixer 2).

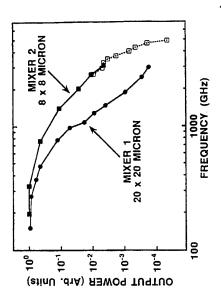
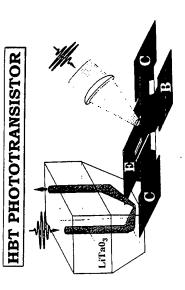
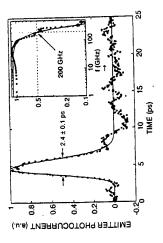


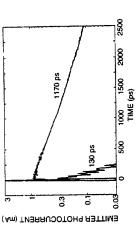
FIG. 2. Comparison of output power from mixer 1 and mixer 2. In both cases the pump lasers are Ti:Al₂O₃ lasers operating at $\lambda = 780$ nm.



On-wafer electro-optic sampling geometry.



Electrooptic response of covered-base HBT with nulled-out slow component. Symbols—experimental points; solid lines—Gaussian and exponential components numerically fitted to the data.



Comparison of slow time constant components with and without 50-\text{\text{1}}-impedance base termination.

OPTICAL RECTIFICATION

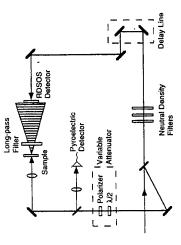
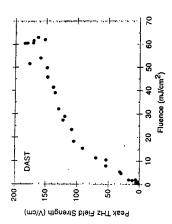


FIG. 1. A schematic of the experimental setup used for the THz optical rectification measurements.



Rectified field strength plotted as a function of incident optical fluence using a 0.6-mm-thick DAST emitter.

THZ PULSES FROM THE CREATION OF POLARIZED EXCITONS

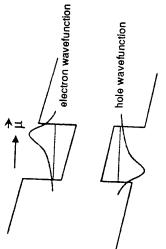


Fig. 1. Diagram of the envelope wavefunctions of the electron and hole in a biased quantum well. The electric field shifts the electron and hole wavefunctions to opposite sides of the well, creating a dipolemoment.

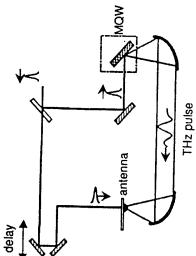


Fig. 3. Measured THz waveforms from the quantum wells at 77 K for several field strengths. The inset shows the peak amplitude of the waveforms (in arb. units) as a function of field strength in the quantum wells. The solid line is a calculation of the field-induced polarization

<u>(3</u>

 $P \sim \left| \left\langle \Phi_e \left| \Phi_h \right\rangle \right|^2 \left[\left\langle \Phi_h \left| z \right| \Phi_h \right\rangle - \left\langle \Phi_e \left| z \right| \Phi_e \right\rangle \right] \right.$

Тіте (рs)

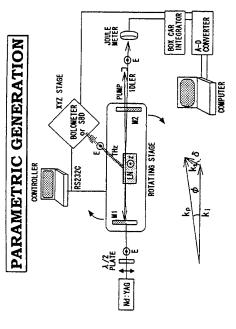


FIG. 1. Experimental setup for the generation of coherent tunable THz wave. The inset shows the momentum conservation relation among the pump, near-infrared idler, and THz signal.

Experimental configuration. A

femtosecond laser pulse strikes the multi quantum well sample MQW. A parabolic mirror collects the generated THz radiation and a second one focuses the radiation onto a 50 µm photoconducting

antenna, gated by the second laser pulse.

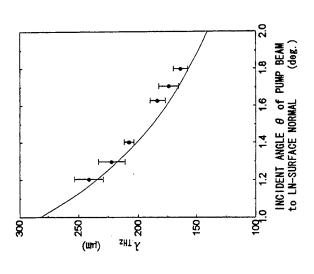
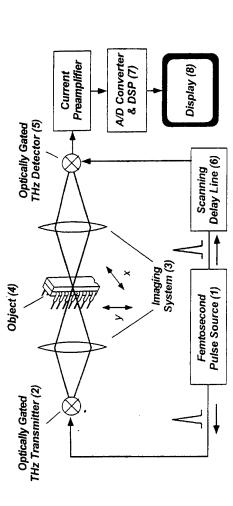
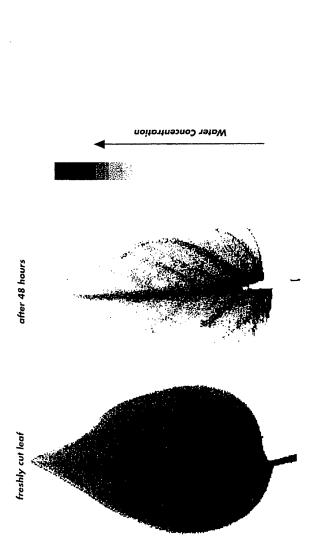


FIG. 2. Characteristic of wavelength tuning of THz wave: (a) shows an example of the wavelength measurement using the etalon, and the result was summarized in (b). Solid curve indicates the calculated tuning curve.

IMAGING WITH TERAHERTZ WAVES

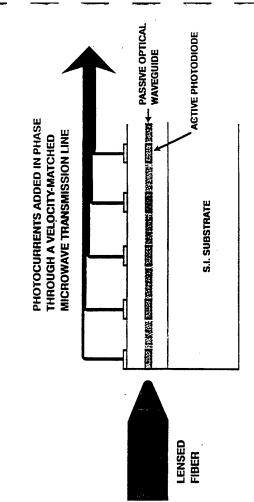


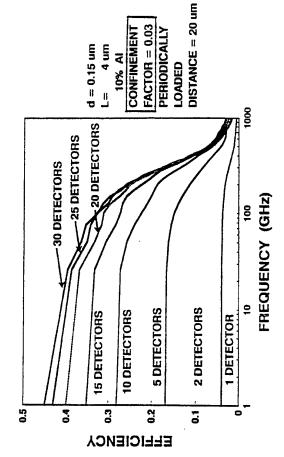
Schematic of the TH2 imaging system. In our experiments the object is raster scanned



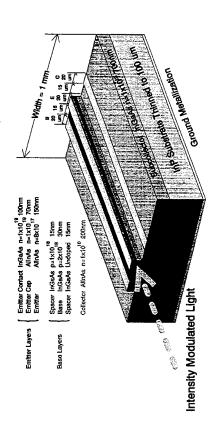
Left: THz image of a fresh leaf. Attenuation of THz radiation through the leaf is largely due to water Right: THz image of the same leaf after 48 b. Water has clearly evaporated from the leaf

PRINCIPLE OF THE ULTRAFAST PMT



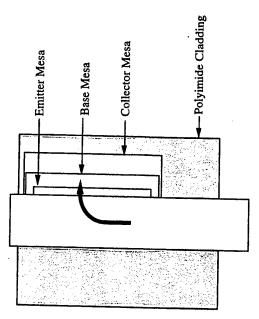


The Traveling Wave HPT Solution



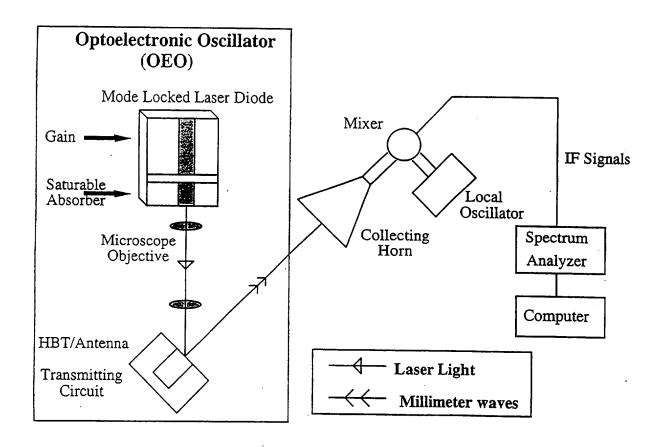
- Supports optical and electrical traveling waves
- Bandwidth limitation based on velocity mismatch
- Separates electrical and optical optimization
- \bullet Characteristic impedance designed for 50 Ω
- Long device improves optical coupling and absorption

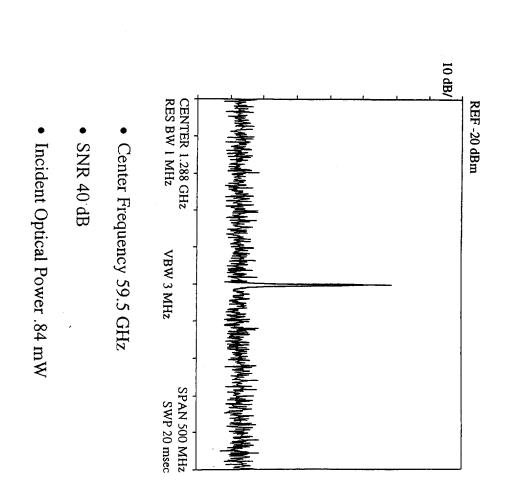
TW-HPT With Integrated Polyimide Optical Waveguide



Polyimide Waveguide

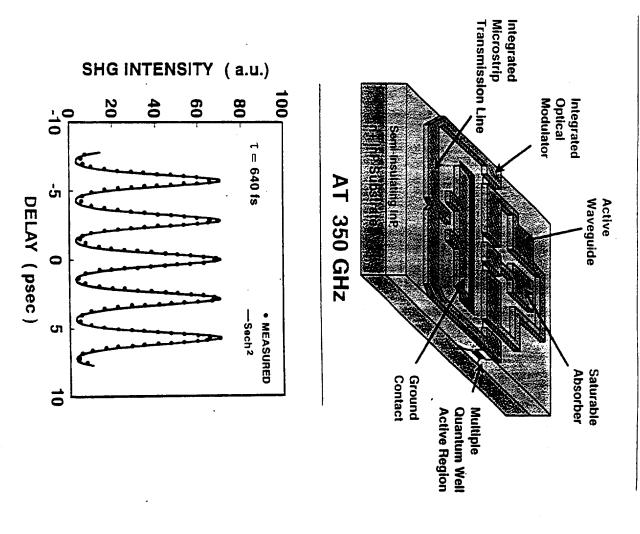
- Optical Signal Leaks into Base/Collector Region Via Side Coupling
- Absorption of Intensity Modulated Optical Wave Induces Electrical Traveling Wave Signal
- Use of Polyimide Waveguide Reduces Velocity Mismatch Between Optical Wave and Electrical Wave Resulting in Broadband Operation
- Optical Coupling Efficiency can be maximized
- Electrical Waveguide Characteristic Impedance Designed for 50 Ω Match to External Circuit

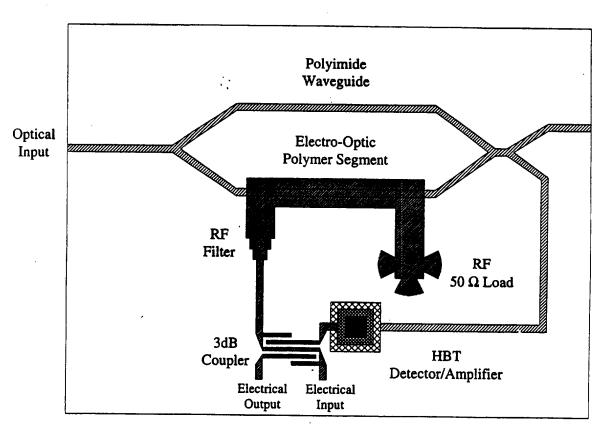




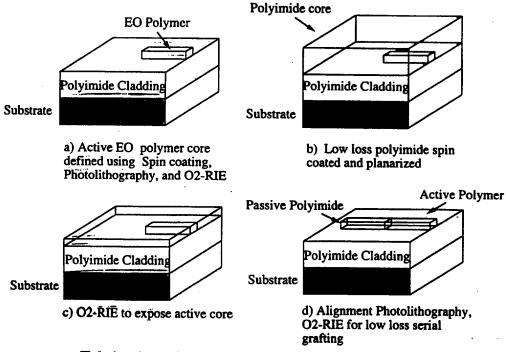
Millimeter Wave Radiation

Monolithic Colliding Pulse Mode-Locked (CPM) Diode Lasers

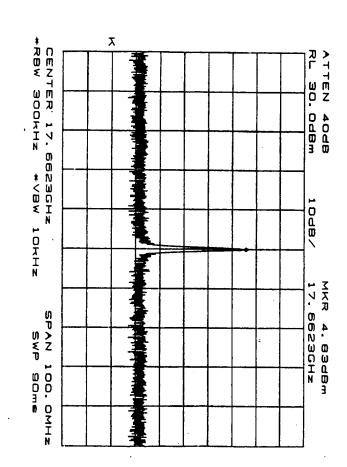




Optical Output



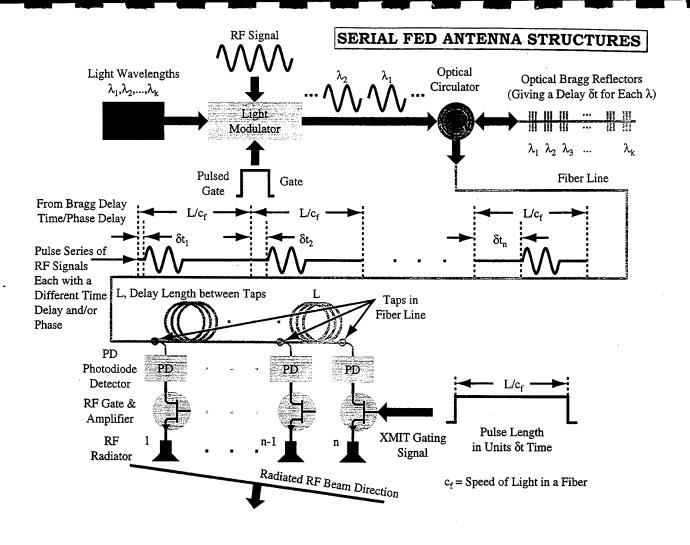
Fabrication of low loss connection between active polymer and low loss polyimide



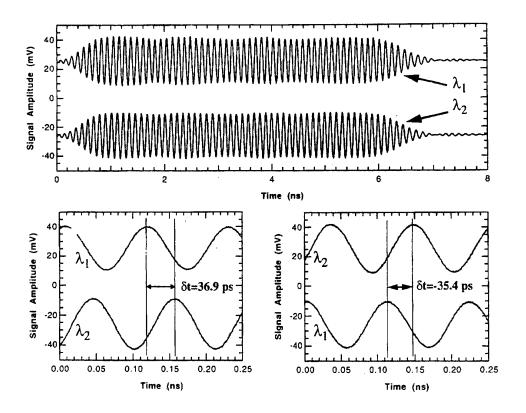
3 dB Linewidth = 330 kHz

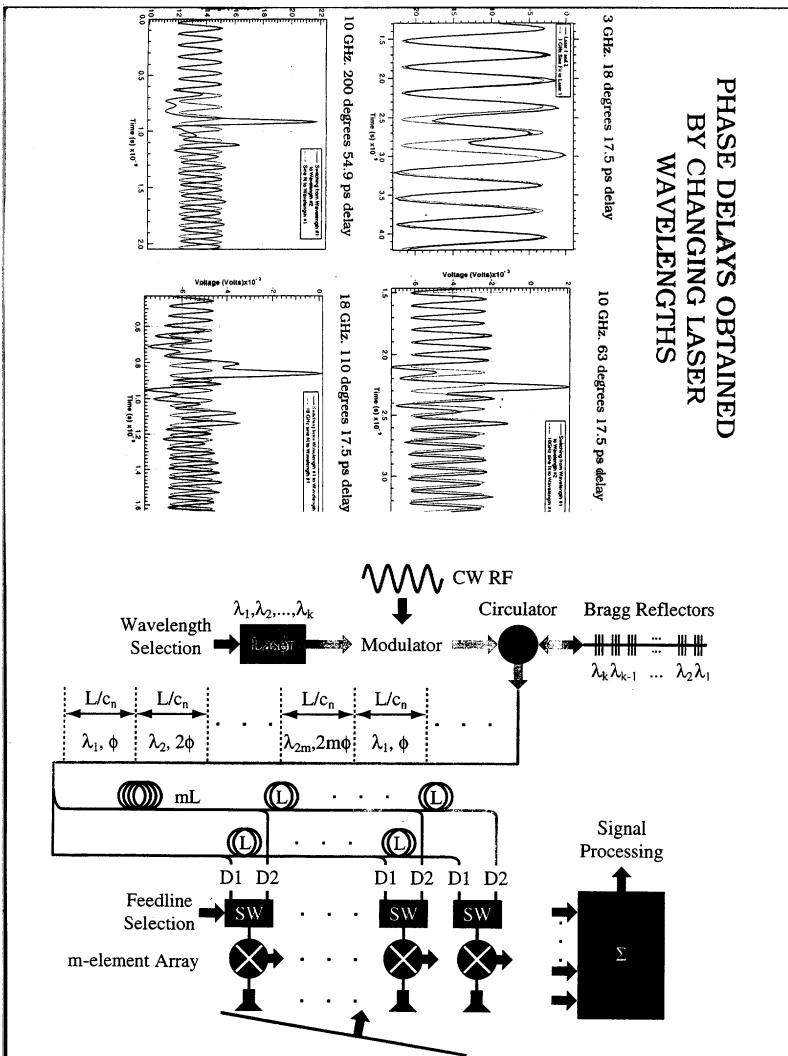
Center Frequency = 18 GHz

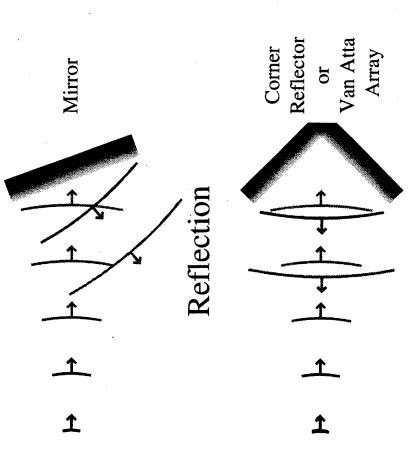
SNR = 42 dB



• Serial Feed Concept: Experimental results at 9 GHz



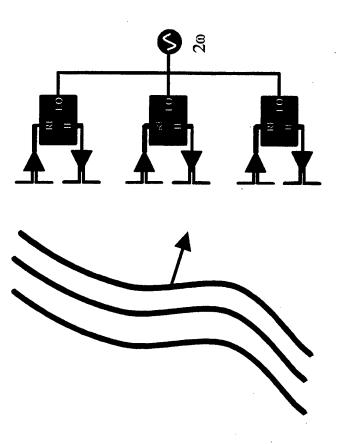




Regular Retrodirectivity

Basic concept:

Instead of using the nonlinearity of materials, we use the nonlinearity of mixers' V-I characteristics



Through the nonlinear response of the mixer, there will be a current component:

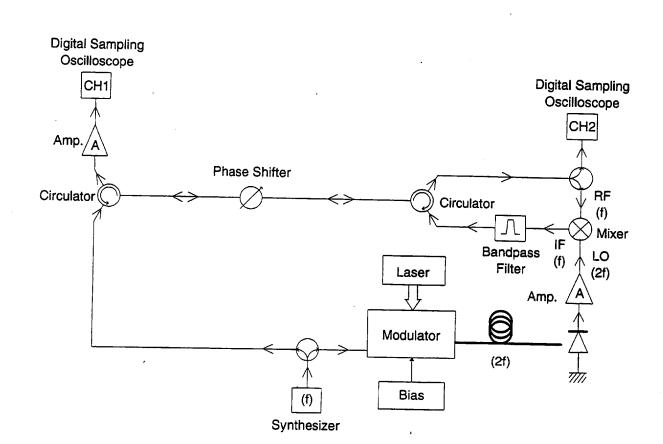
$$I_3 = cV_1^*V_2 = cB_1B_2e^{i(wt+\phi_j)}$$

This current drives the radiating antenna to generate an *E*-field:

$$\mathbf{E}_{C}(\mathbf{r}_{j}) = \mathbf{A}_{3}e^{i(\omega t + \phi_{j})}$$

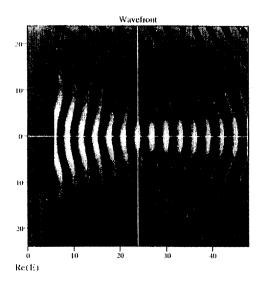
This field is conjugate to the incoming field at \mathbf{r}_j

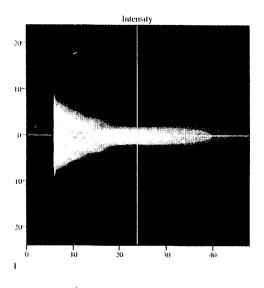
If we can generate $\mathbf{E}_{c}(z=0)$ for all x,y, we will have $\mathbf{E}_{c}(\mathbf{r})$ for all \mathbf{r}



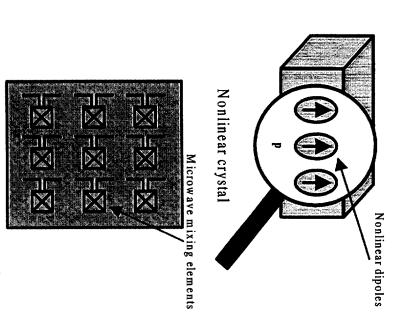
Experimental setup of conjugate phase generation using optically pumped microwave mixers

10-element dipole antenna array, 2/3 λ apart

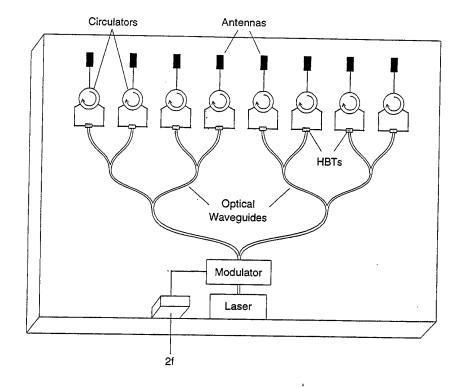




Artificial nonlinear microwave surfaces:

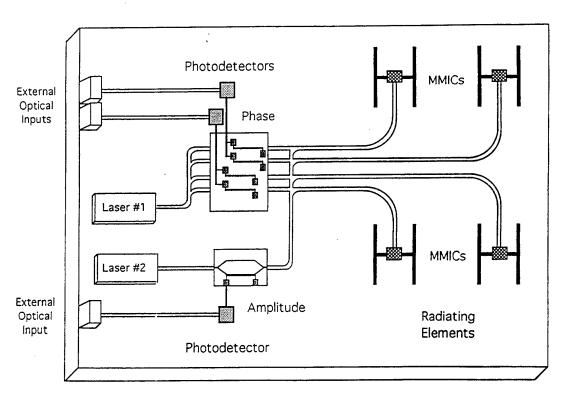


Artificial nonlinear microwave surfaces



Two dimensional microwave nonlinear optically pumped surfaces

Wafer Scale Integration



CONCLUSION

- * NEW OPTICAL/TERAHERTZ SOURCES
- * FIBER TRANSMISSION CAPABILITY
- * OPPORTUNITY FOR NOVEL SYSTEMS
- * MODE LOCKED SEMICONDUCTOR LASERS
- * ELECTROOPTIC POLYMERS

FIELD IS NOW AT AN EXCITING

STAGE

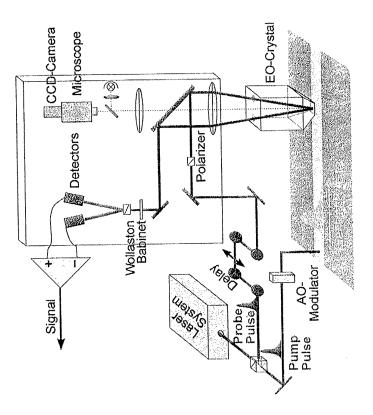
Optical and Electrical Generation of Terahertz Pulses and Imaging Techniques

by

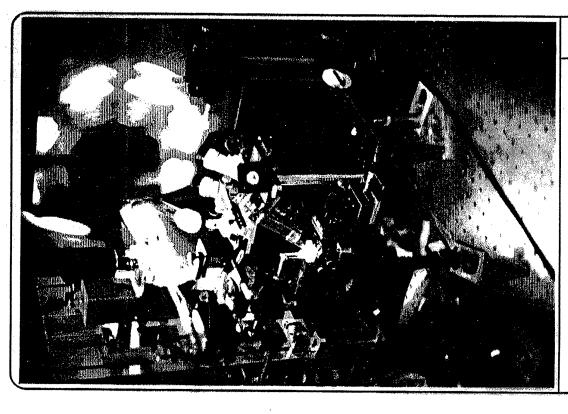
H Roskos

RWTH Aachen Germany

Impulsive Characterization Pump/Probe Measurement Scheme

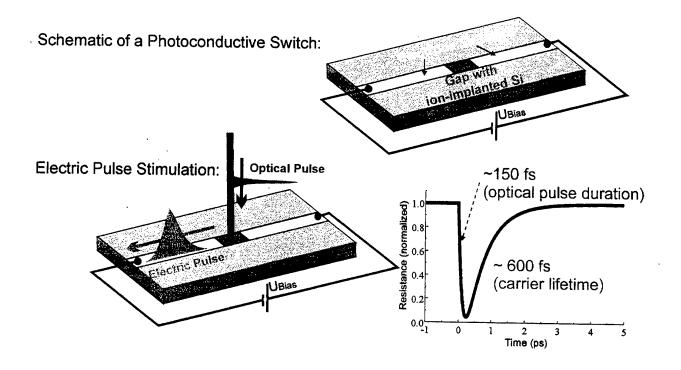


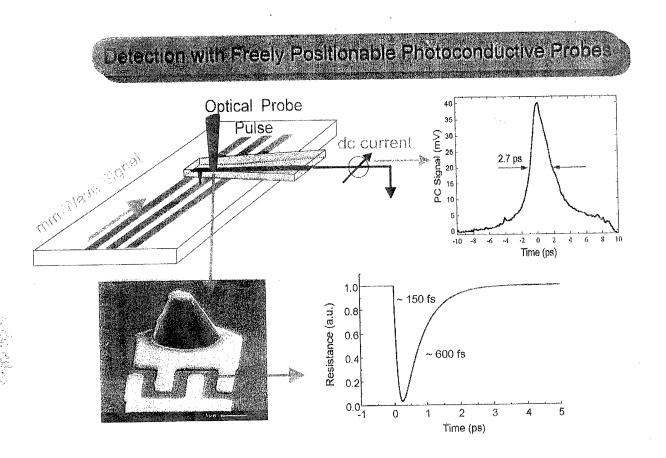
Pump and probe laser pulses originate from the same pulse => no jitter => very high time resolution



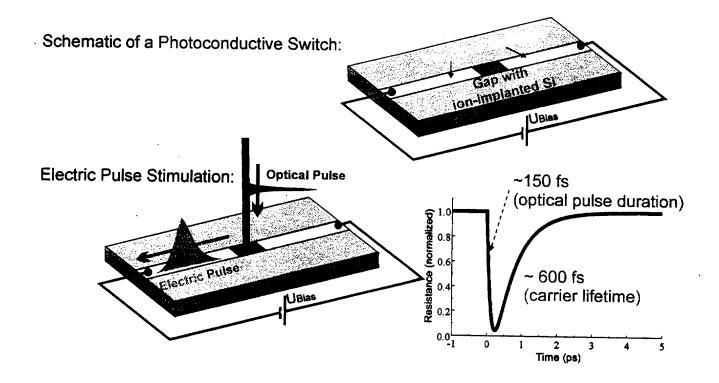
Institut für Halbleitertechnik II, RWTH-Aachen

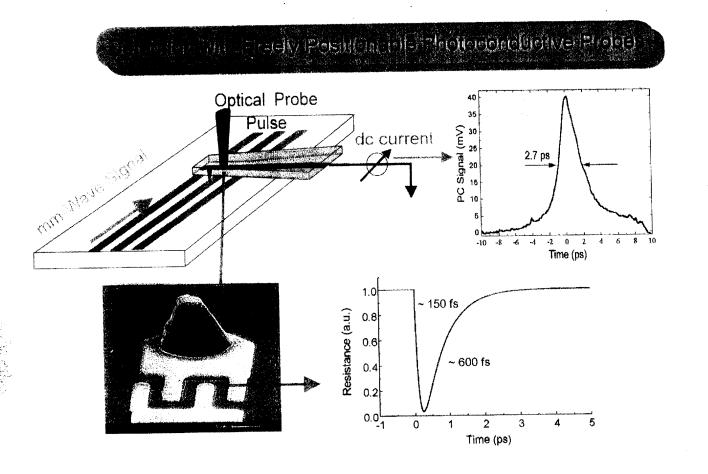
Generation of Picosecond Electric Pulses



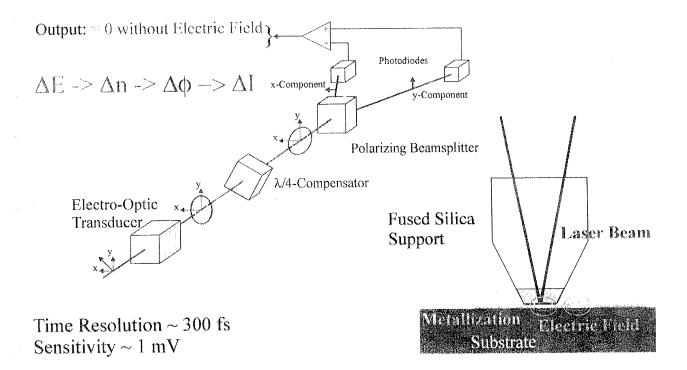


Generation of Picosecond Electric Pulses



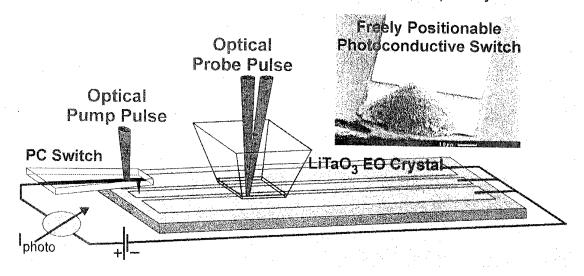


Electro-Optic Detection of Electric Fields

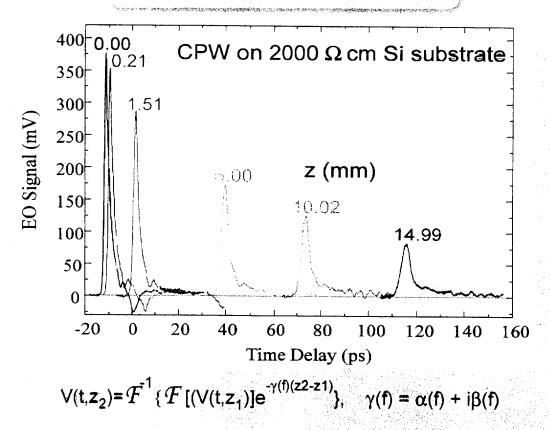


Optoelectronic Characterization

- laser source: Ti:sapphire laser (150 fs, 740 nm, 500 mW)
- pump/probe set up
- ps electric pulse generator: freely positionable photoconductive switch
- ps electric pulse detector: freely positionable electro-optic crystal

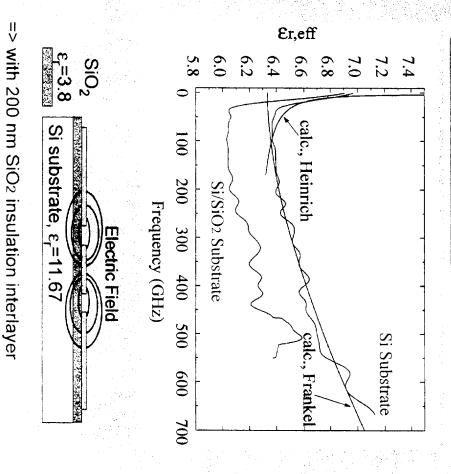


Time Domain Waveforms on a CPW





6.5% decrease of Er,eff



Insulation Layer on e_{reff}

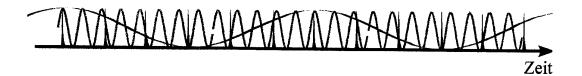
Synchronisation eines frei laufenden Ti:Saphir-Lasers auf einen freilaufenden GHz-Oszillator

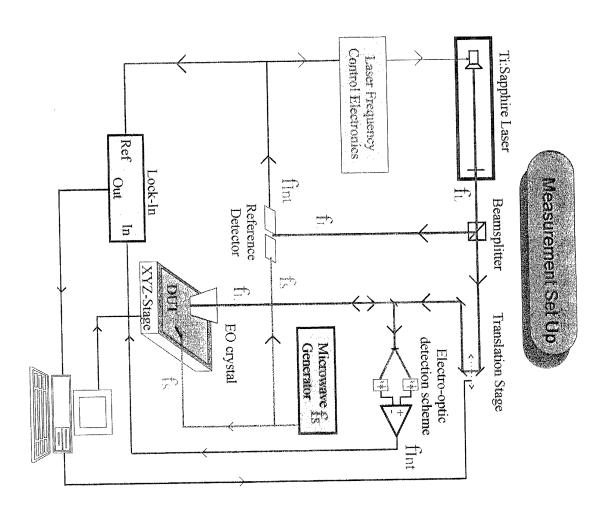
Meßprinzip:

Mischung eines periodischen Millimeterwellensignals (fsig) mit einer höheren Harmonischen der Laserpulswiederholfrequenz (fL)

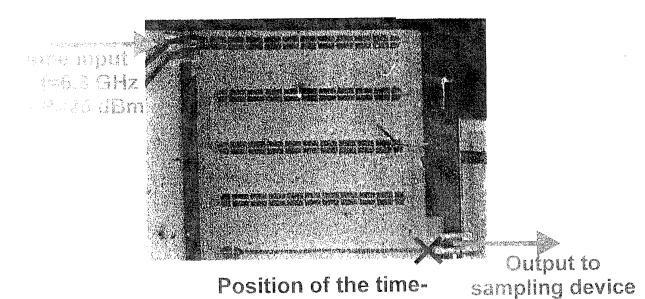
=> Abbildung des Millimeterwellensignals bei einer Zwischenfrequenz fint

$$f_{ln\ell} = f_{Sig} - n \times f_L$$



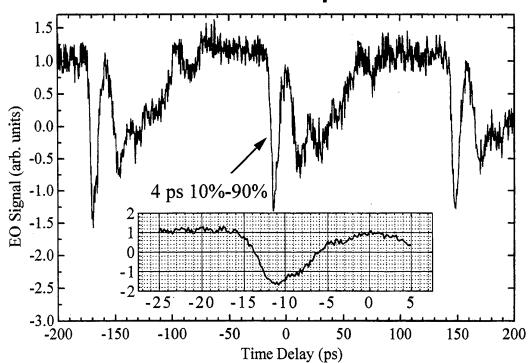


Fast Transients on a Nonlinear Transmission Line (NLTL)



Waveform at the Output of the NLTL

resolved measurement

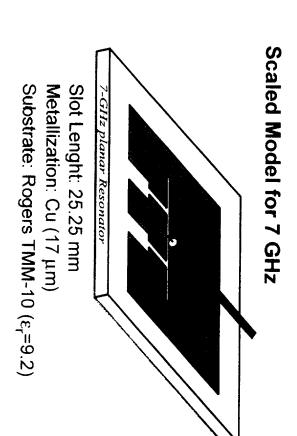


A Monolithic Integrated Millimeter Wave Transmitter for Automotive Applications

Azel Stiller, Erwin M. Bieth, Member, IPEE, L.F. Lay, Member, IPEE, Karl M. Strohn, and Josef Hunchler, Atomber, IEEE

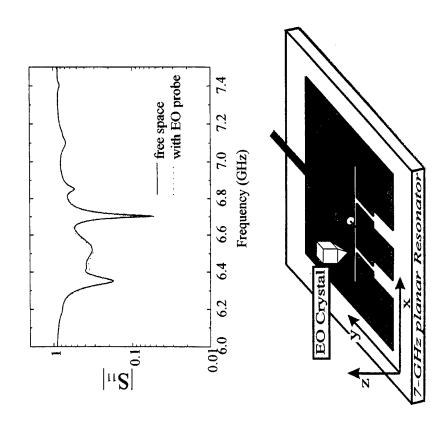
this device finds many applications in civil sensus and communiation systems and is complayed in automotive applications. The facine consistency of the MANT I doubt and a slottled patch resonation. The resonation arts, simultaneously as an automate The resonation in pediance seen by the MANT I doubt on a steelar of the resonation in pediance seen by the MANT I doubt of the BMAT I doubt is needigated using a large signed analysis. The transmitter dock is used keep fabricated employing a SIMMANT Collect in radiated some rad up to 1 may at 79 GHz. An excellent currier do-anise with of \$1.7 dHe/Hz at an offset of 190 kHz has been achieved. The deviation of the measured radues from the theoretically redicted values of frequency and power is ~5.9% and 1.5 dB.





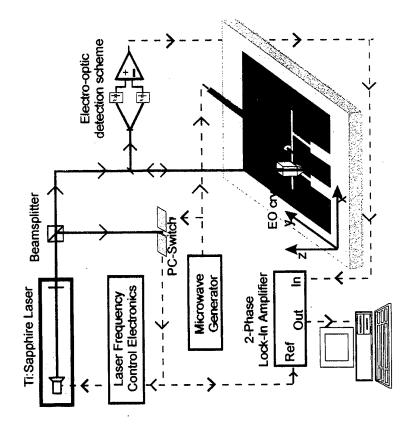
ON THE CONTROL OF THE PROPERTY OF THE PROPERTY

Electrical Characterization

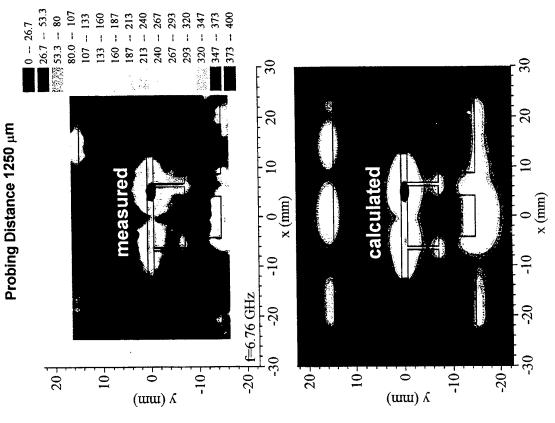


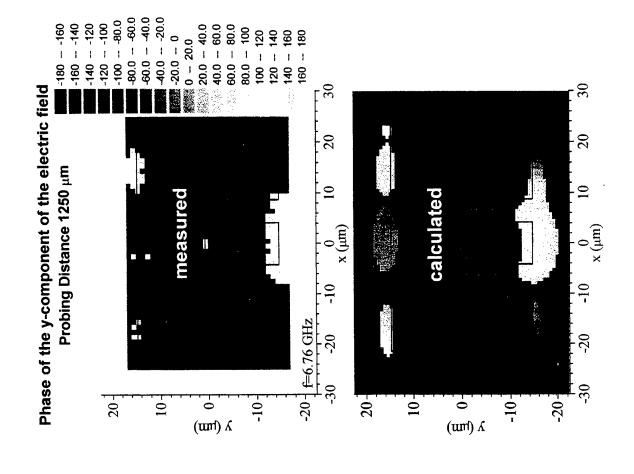
=> noninvasive testing with EO probe

Experimental Set Up For Electric Near Field Mapping

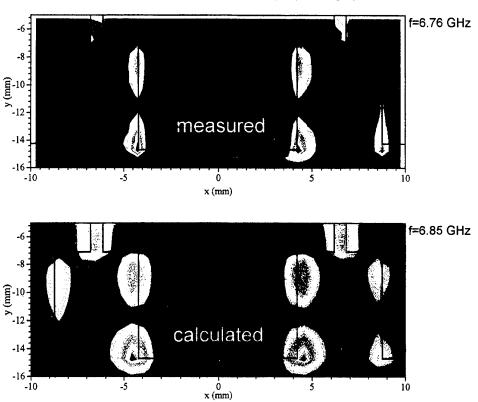


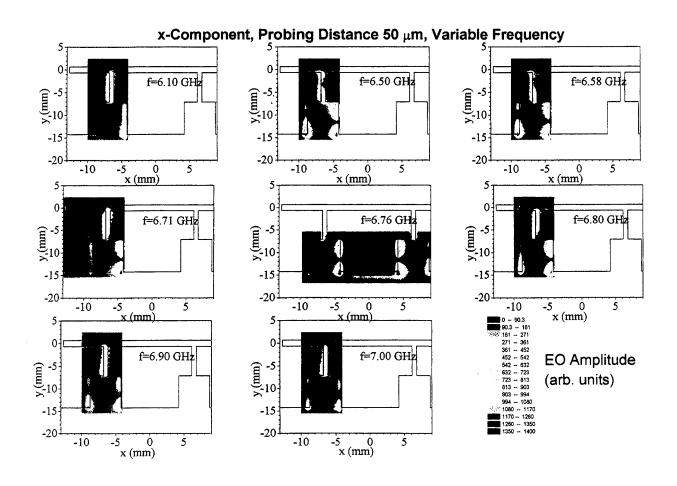
Magnitude of the y-component of the electric field





Magnitude of x-component (50 μm height)





x-Component, f= 6.76 GHz, Variation of the Probing Distance h=50 μm h=700 µm (mm) x Normalized Peak Amplitude 0 -- 3.23 3.23 -- 6.45 -15 6.45 -- 9.68 9.68 -- 12.9 10 10 -10 0 x (mm) 0 x (mm) **55 12.9 -- 16.1** 16.1 -- 19.4 19.4 -- 22.6 h=200 μm h=1000 µm 22.6 -- 25.8 25.8 -- 29.0 -5 -5 (in the state of t 29.0 -- 32.3 32.3 -- 35.5 35.5 -- 38.7 38.7 -- 41.9 41.9 -- 45.2 -15 -15 48.4 -- 51.6 0 x (mm) 0 x (mm) ż 10 -10 10 -10 51.6 -- 54.8 54.8 -- 58.1 58.1 -- 61.3 h=1300 μm h=500 µm 61.3 -- 64.5 -5 64.5 -- 67.7 (mm) 10 10 67.7 -- 71.0 71.0 -- 74.2 74.2 -- 77.4 77.4 -- 80.6 -15 **80.6 -- 83.9** 83.9 -- 87.1

-10

x (mm)

10

LASER-DRIVEN BLOCH OSCILLATIONS IN SEMICONDUCTOR SUPERLATTICES

-10

87.1 -- 90.3

90.3 -- 93.5

93.5 -- 96.8 96.8 -- 100

10

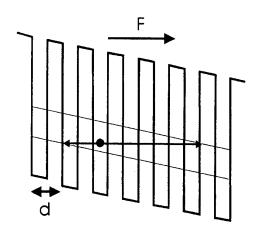
x (mm)

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R. Martini, F. Wolter, P. Haring Bolivar, C. Waschke,
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BLOCH OSCILLATIONS IN PERIODIC POTENTIALS

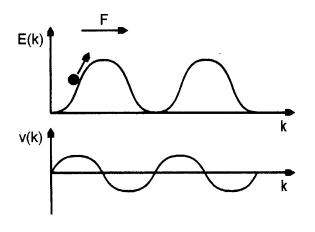
Electronic wave packet in a periodic potential (period: d) superimposed with an homogeneous electric bias field F



Spatial oscillations of the wave packet because of Bragg reflections

SEMICLASSICAL PICTURE OF BLOCH OSCILLATIONS

Electron wave packet in a periodic potential (period: d) subjected to a uniform electric field F



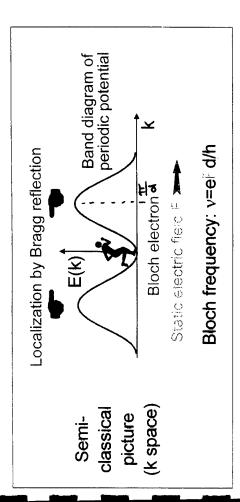
Bloch (1928): Wave packet moves with constant velocity ħdk/dt = eF through k-space

Real-space velocity: ħv(k)=dE/dk

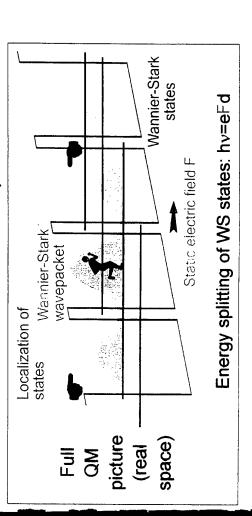
Zener (1934): Spatial oscillations with Bloch frequency

ν_в=eFd/h

BLOCH OSCILLATIONS



Realization: Quantum interference in the Wannier-Stark ladder of a superlattice



DETECTION OF BLOCH OSCILLATIONS

Time-resolved detection of Bloch oscillations by three different techniques:

- 1. Four-wave mixing: Third-order interband polarization P⁽³⁾(t)
- THz-emission spectroscopy: Detects emitted coherent electromagnetic transients
- 3. Electrooptic probing: Detects internal electric-field changes
- Feldmann et al., PRB 46, 7252 (1992); Leo et al., Sol. State Commun. 84, 493 (1992); Leisching et al., PRB 50,14389 (1994).
- 2. Waschke et al., PRL 70, 3319 (1993); Roskos, Adv. Sol. Phys. 34, 297 (1994)
- 3. Dekorsy et al. PRB 50, 8106 (1994) and PRB 51, 17275 (1995)

THz emission:

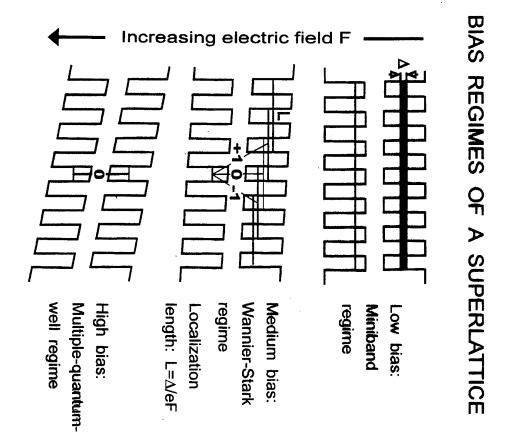
Emitted electric field: $E_{THz}(t) \sim \frac{\partial j(t)}{\partial t}$

(t): Quantum-mechanical current density

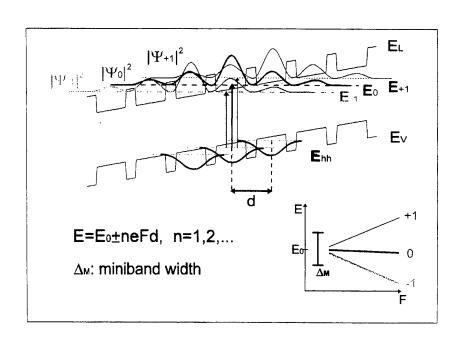
 $j(t) = j^{(2)}(t) = 2\pi e/h \int_{k} \partial \varepsilon(k)/\partial k C_{k} dk,$

 $C_k = \langle c_k^{\dagger} c_k \rangle$: Occupation density of electrons or holes

- ▶ Emission efficiency?
- Dephasing times and dephasing mechanisms?
- Properties of excitons or continuum electrons?

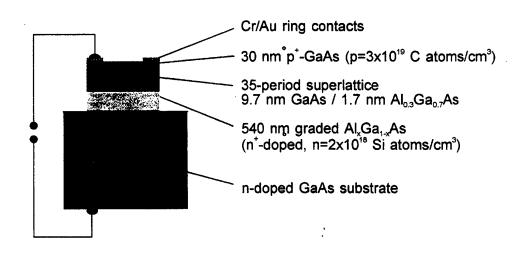


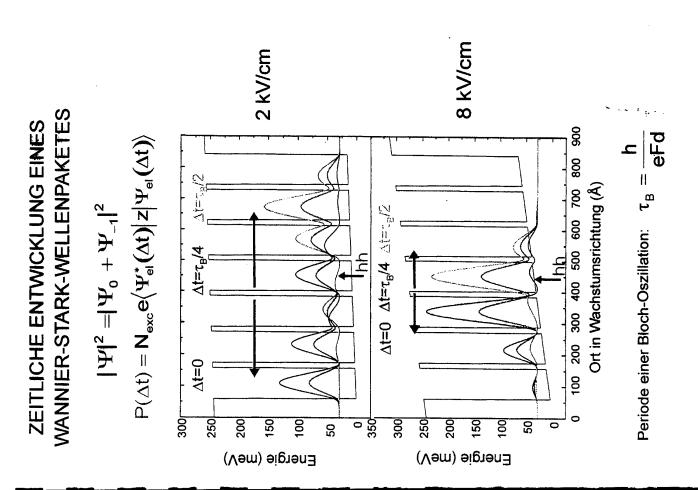
Generation of Bloch oscillations by simultaneous excitation of excitonic and/or continuum Wannier-Stark resonances with an ultrashort laser pulse



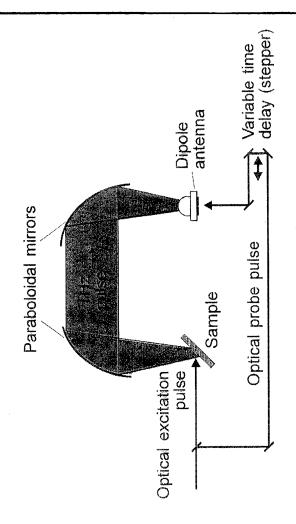
SAMPLE DESIGN

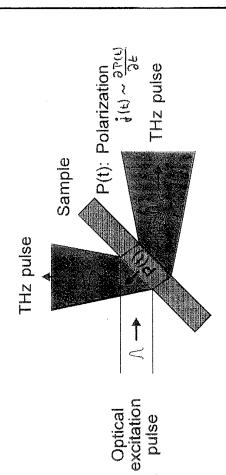
Superlattice structure as the intrinsic region of a pin diode Sample patterned into 450-μm mesas





EXPERIMENTAL SETUP FOR THZ-EMISSION SPECTROSCOPY

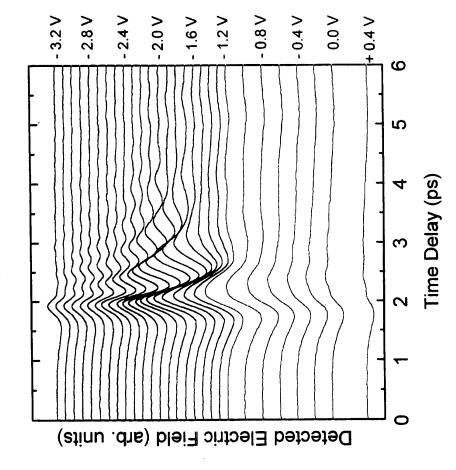


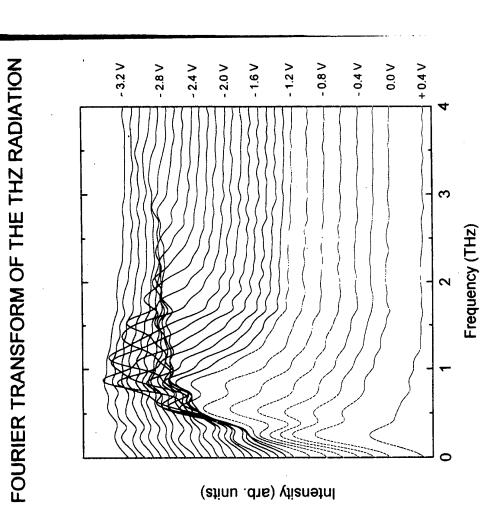


THZ-EMISSION FROM BLOCH OSCILLATIONS

Minibandwidth: 18meV

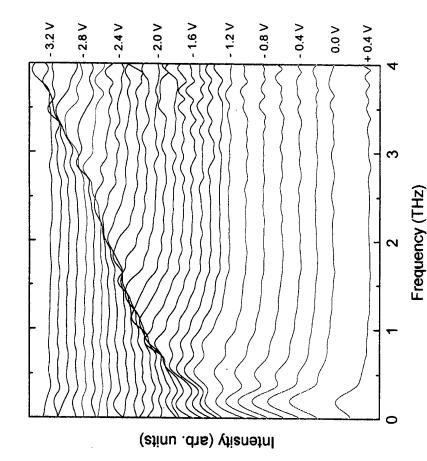
 $T=10 \text{ K}, n=10^9 \text{cm}^{-2}$



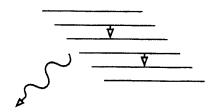


FOURIER TRANSFORM OF TERAHERTZ RADIATION





EFFICIENCY OF THZ-WAVE EMISSION



Energy of the emitted coherent radiation is extracted by Wannier-Stark ladder transitions

Questions to be addressed:

- What determines the emitted power?
- How to increase the emission efficiency?

COHERENCE AND EMITTED POWER

$$|(t) \sim |E_1(t)|^2$$

Coherent emission into the same electromagnetic mode:

$$I_{coh}(t) \sim |E_1(t)+E_2(t)|^2$$

Emission with same phase, same amplitude:

$$I_{coh}(t) \sim 4 |E_1(t)|^2$$

Coherent emission into one electromagnetic mode (= SEFERRADIANCE) is more efficient than incoherent emission: $I_{coh}(t) = 2 I_{incoh}(t)$

SUPERRADIANT THZ EMISSION

 $E_{max} = N \Delta E$: Interlevel energy available for coherent emission, N: Initial number of electrons



P_{rad}: Power of emitted radiation

$$\gamma_{rad} = P_{rad} / E_{max}$$
: Radiative transition rate

1 / γ_{rad} : Radiative lifetime

$$\gamma_{\text{rad}} = \frac{\Delta E^3 e^2 \mu^2}{6\pi \hbar^4 c^3 \epsilon_0} N^{\dagger}$$

Dicke, Phys. Rev. 93, 99 (1953) Victor et al., JOSA B 11, 2470 (1994)

 N_{I} : Number of cooperatively emitting dipoles

 N^{l} = 1: Spontaneous emission rate

An increase of N_I results in an increase of the radiative transition rate. Complete energy extraction, if: $1/\gamma_{rad}$ < dephasing time

COOPERATIVE EMISSION

a» λ

Initial THz radiation power P(t=0)=P₀ in each emission cone:

$$P_0 = \frac{e^2}{4c\epsilon_0 n^1} Z_{Bloch}^2 \omega^2 n^2 F \frac{\sin^2(\beta)}{\cos(\beta)}$$

n': index of refraction of semiconductor

n: volume density of carriers

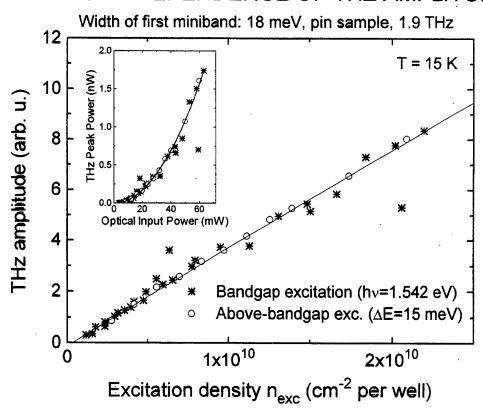
β: internal beam angle

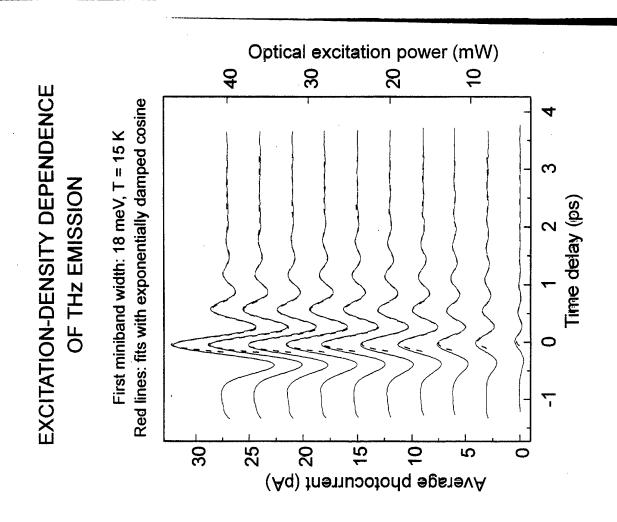
Z_{Bloch}: electron-hole separation matrix

2 Z_{Bloch}: full spatial amplitude of Bloch oscillation

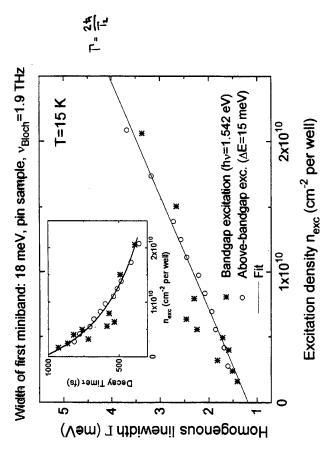
Measurement of $P_0(\omega)$ => amplitude $Z_{Ploch}(\omega)$

DENSITY DEPENDENCE OF THZ AMPLITUDE





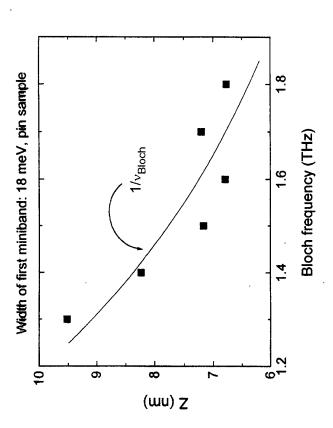
DENSITY DEPENDENCE OF DEPHASING



(I) Fit function: $\Gamma(n_{\rm exc}) = 1.18 \, {\rm meV} + \gamma \, a^2_{\rm Bohr} \, E_{\rm Bohr} \, n_{\rm exc}$ $\gamma = 15 \, {\rm for} \, a_{\rm Bohr} = 10 \, {\rm nm}, \, E_{\rm Bohr} = 6 \, {\rm meV}$ Corresponds to dephasing measured in four-wave mixing for excitons in quantum wells in the presence of free carriers

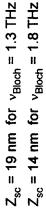
(II.) Dephasing for predominant excitation of free carriers (hv=1.557 eV) is not faster than dephasing of excitons alone (hv=1.542 eV)

SPATIAL AMPLITUDE OF BLOCH OSCILLATIONS



(I) Z determined from detected power of the THz radiation

(II) Semiclassical theory: Amplitude $Z_{sc} = 0.5 \Delta d / (h v_{Bloch})$





(III) 1/vBloch dependence of Z proven.

Factor of two difference between semiclassical prediction and measurement

SUMMARY: COOPERATIVE (SUPERRADIANT) EMISSION

Emitted peak power Po:

- Quadratic scaling of P_o with n
- Achieved: 2 nW at 60 mW pump
- 5 % output coupling through 30 nm p⁺ top contact (58% Drude absorption, 37 % reflection loss)

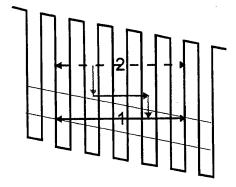
Dephasing time τ:

- Decrease with n
- $n=2x10^{10} / cm^2 well$: $\tau = 0.4 ps (radiative lifetime: 10-100 ps)$
- Dependence on n like that of interband polarization of ensemble of 2D excitons and free carriers
- But in contrast to interband polarization: same dephasing times for excitons and continuum electrons

Spatial oscillation amplitude ZBloch:

• Frequency dependence follows roughly the $1/v_{\mbox{\tiny Bloch}}$ dependence of the semiclassical theory

BLOCH OSCILLATIONS OF ELECTRONS EXCITED HIGH INTO THE CONDUCTION BAND



Case 1:

Bloch oscillations of electrons/ excitons at the band edge

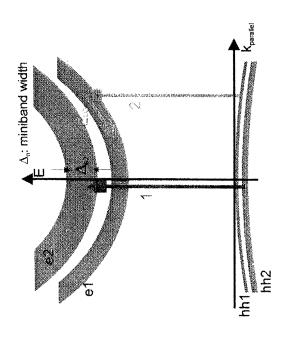
Case 2:

Electrons in high-lying continuum states. Expectation:

- No FWM signal => Bloch oscillations not expected
- For excess energy > LO-phonon energy E_{Lo} : Phase coherence expected to decay within phonon scattering time (~ 200 fs) => Bloch oscillations with ν < 5 THz not expected

EXCITATION HIGH ABOVE THE BANDGAP

(light-hole minibands omitted)



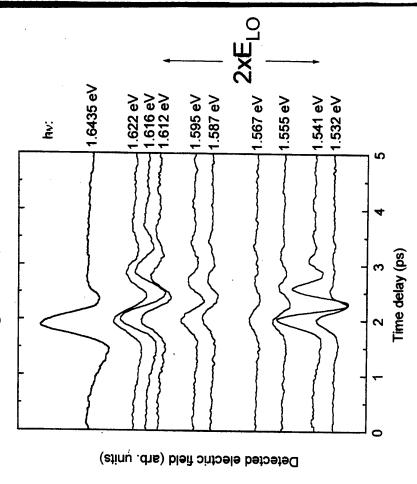
Two explanations for the experimental data:

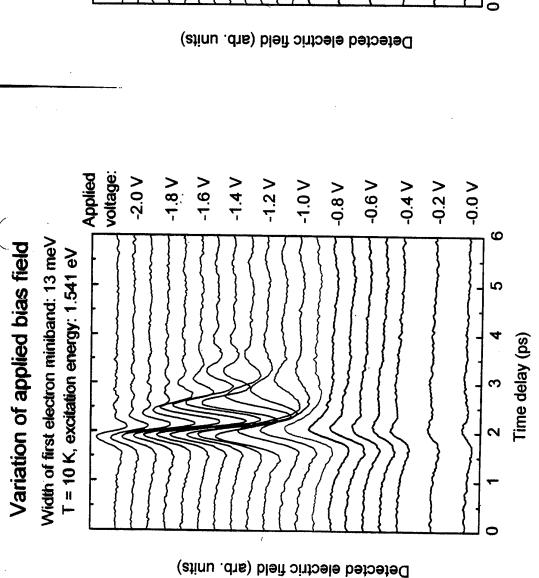
- Bloch oscillations of unscattered carriers in high-laying states:
 - Implies surprisingly long relaxation times.
- 2. Bloch oscillations after carrier scattering: Implies conservation of intraband coherence during scattering

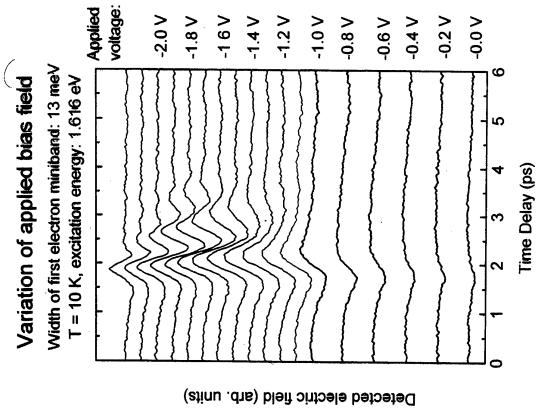
Variation of excitation photon energy

Width of first electron miniband: 13 meV

Bias voltage: -1.5 V, T = 10 K

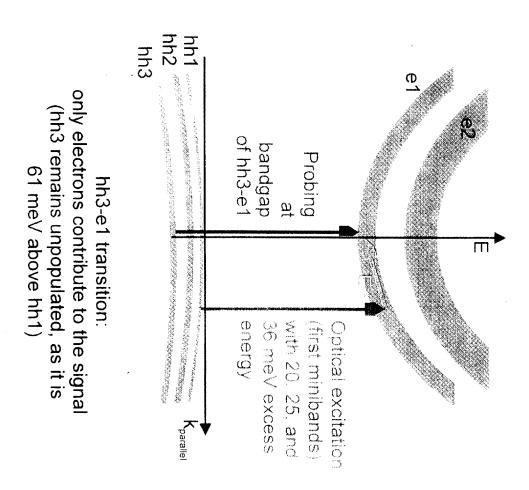






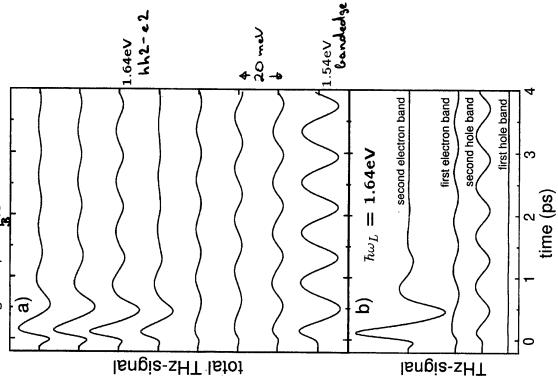
Photocurrent spectrum 15 Miniband width: 13 meV T = 10 KBias: 0 V Photocurrent (nA) 10 hh2-e2 hh1-e1 5 [hle1] 19-2 co Bloch oscillations 0 1.55 1.50 1.65 1.60 1.70 Photon energy (eV)



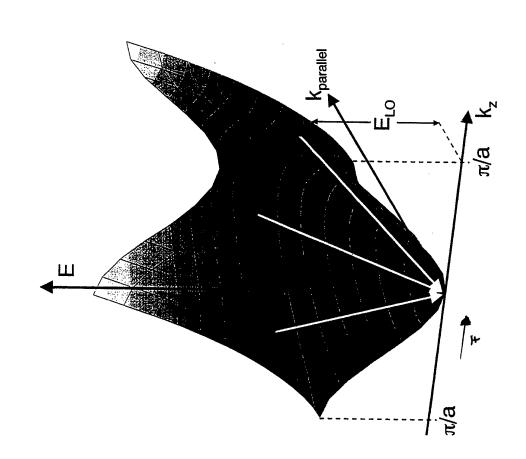


Increasing energy excess Width of 1st electron miniband: 18 meV, $n_{\rm exc} {=} 10^{10}\, {\rm cm}^{-2}$ **ELECTRON RELAXATION VIA LO-PHONON EMISSION** Rise time: 150 fs Rise time: 400 fs Rise time: 370 fs hh3-e1 ∆E=25 meV ∆E=36 meV :\E=20 meV An armonymouth hh3-e1 Time delay (ps) hh3-e1 0.0 0.0 pm 0.1 0.5 0.5 0.5 1.0 1.0 Relative transmission change

F. Rossi et al., Phonon-induced suppression of Bloch oscillations in semiconductor superlattices: A Monte Carlo investigation, Were 3



"BUNCHING" EFFECT OF CHARGE CARRIERS IN K-SPACE



ELECTRONS IN THE FIRST MINIBAND

COMPARISON OF THE COHERENT AND THE INCOHERENT CARRIER DYNAMICS

Measurement of population dynamics:

E<E_{Lo}: Relaxation with a time constant of 400 fs

E>E_{Lo}: Relaxation within ≤200 fs

Coherent THz dynamics:

Decay time constant of THz oscillations: 750-1000 fs (for all excess energies E<E $_{\rm Lo}$ and E>E $_{\rm Lo}$)

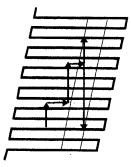
CONCLUSION:

Bloch oscillations are observed in spite of energy

relaxation of electrons.

=> Evidence for partial phase conservation during relaxation

by LO-phonon emission.



SUMMARY: BLOCH OSCILLATIONS UPON EXCITATION WELL ABOVE THE BANDGAP

Bloch oscillations continue even after emission of 1 or 2 LO phonons

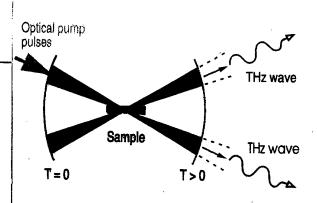
- Indication for intraband phase conservation during LO-phonon emssion
- Phase retardation of the coherent charge oscillations observed.

Explained by "bunching effect": Uniform and quasi-simultaneous momentum transfer from LO phonons.

DO NOT AFFIX OVERLAYS ALONG THIS SURFACE

FEEDBACK IN A RESONATOR: AN EXAMPLE FOR "LASING WITHOUT INVERSION"

Lu, Opt. Commun. 38 (1990) 1684



Overall gain with phase-correct feedback consists of:

- Superradiant gain
 (cooperative emission from the coherent ensemble)
- Lasing gain (with inversion) or absorption loss (higher levels less populated than lower levels)

THURSDAY JULY 11

Multi-Giga-Hertz Optoelectronic Devices

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World Wide Web http://www.elec.gla.ac.uk/~ironside/

Abstract.

Topics from device technology for multi-gighertz integrated optoelectronic systems are covered; monolithic modelocked semiconductor lasers operating at pulse rates up to 375 GHz, and very high speed electroabsorption modulators employing a resonant funneling diode

Acknowledgements:

Monolithic modelocking :J. F. Martins-Filho ,Unversity of Pernabucco, Recife, Brasil, E. A. Avrutin and S. M. MacDougall, University of Glasgow.

Resonant Tunnelling Diode: S. G. McMeekin Cardiff School of Engineering, University of Wales Cardiff, PO Box 917, Newport Rd Cardiff, NP2 1XH, United Kingdom.

Jose Figueiredo, Universities of Porto and Glasgow.

EPSRC, UK Financial Support:

July 1996

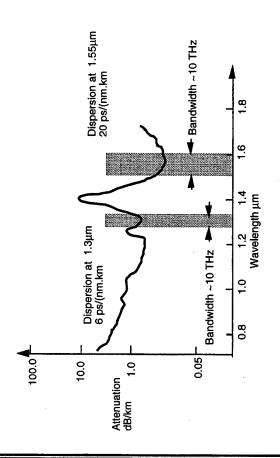


TeraHertz 2

Outline of talk

- * Introduction to high speed optoelectronics
- *High speed Semiconductor laser -monolithic modelocking
- *Resonant Tunneling Diode optoelectronic

Bandwidth of Standard optical fibre



Introduction

* Multi-gigahertz optoelectronic technology is driven by the requirements of optical communication systems *At Glasgow we are working on integrated devices - usually this means on a semiconductor laser chip. Integration -emulates the success of silicon electronics and increase speed, reliability, functionality and manufacturibility *Semiconductor lasers are compact (length about 600µm), robust efficient means of converting electrical power into optical power); (have operated in extreme environments), reliable (10⁶ hours easily), efficient (up to 60% conversion; they are the most they can produce up to 1W from a single stripe

30GHz or so. They can operated in a self pulsating manner (either *They can be directly modulated by a microwave signal up to Q-switched up to 100GHz or modelocked up to 1.5THz)

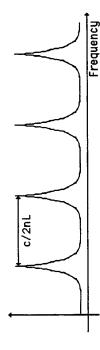
made modelocked laser capable of procducing a plse stream at a *By integrating saturable sections with a laser diode we have repetition rate of up to 375 GHz *Resonant Tunnelling Diodes have been extensively employed in micorowave generation - although this currently low power

*By integrating a RTD structure with an optical waveguide it is possible to make a optical modualtor which has gain at microwave frequencies

July 1996

Basics of modelocking

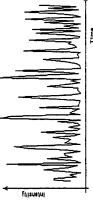
Associated with a laser resonantor of length, I, there are longitudunal modes of separation c/2nl



The time dependence of the electric field of the laser is given by:-

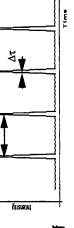
$$E(t) = \sum_{n=0}^{n=N} E_n \exp j(\omega_0 + n\omega + \phi) t$$

If the laser operates in multimode operation then ϕ is a random phase factor because each mode builds up independently from noise The Time domain behaviour of a multimode laser is noisy

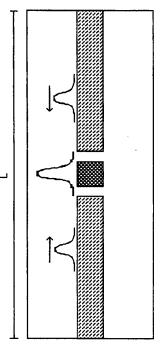


modelocked and the time behaviour of a modelocked laser is If the phase relationship between modes is fixed, the laser is a stream of ultrashort pulses

limited by the bandwidth of The pulse width is ideally the laser



Fixed phase fixed amplitude

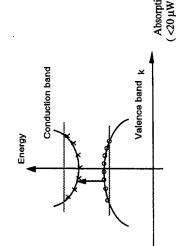


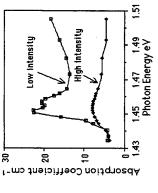
- Saturable absorber region
- Gain regions

Two pulse buid up from noise the laser operates when both pulses collide in a Saturable Absorber

The Saturable absorber

Absorption in a semiconductor is a function of light intensity; an increase in intensity reduces the absorption. Satruable absoprtion can arise when electrons in the conduction band occupy states and block futher transitions.





Absorption spectrum of the Quantum welll exciton at low $(<20~\mu W)$ and high (\approx 10 mW) input intensities. The waveguide rib width is 3 mm and length is 1 mm. The hhand lh-excitons are at photon energies 1.451 eV and 1.458 eV respectively.

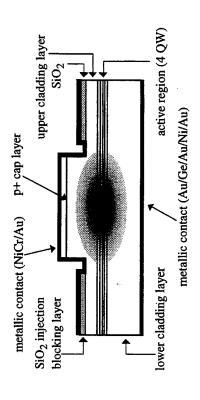
July 1996



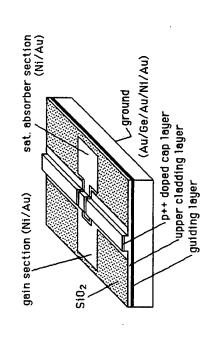
TeraHertz 6

Device cross-section and chip layout

Device cross-section

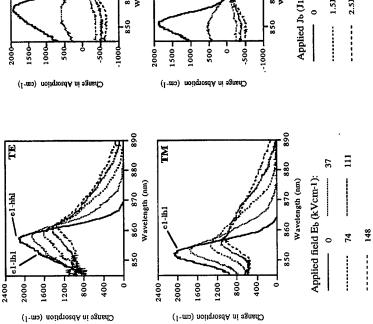


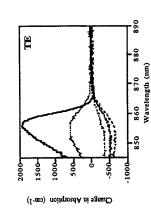
CPM laser chip layout

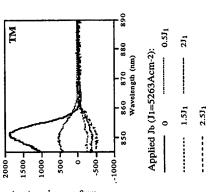


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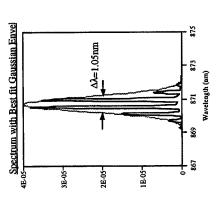
Absorption and Gain spectra of quantum well laser

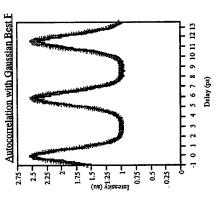






Transform limited pulses from a CPM semiconductor laser





Frequency and time domain measurements of the output from CPM laser show that the pulses are transform limited

The pulse duration is 1ps and the time between pulse is 6 ps repetition rate 166GHz.

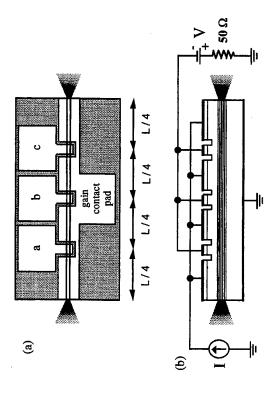
The average power is 8mW implies peak powers of 48 mW

The wavelength is around 860 nm and therefore the photon energy is above the band-gap energy of Si.

a

Multiple colliding pulse semiconductor laser

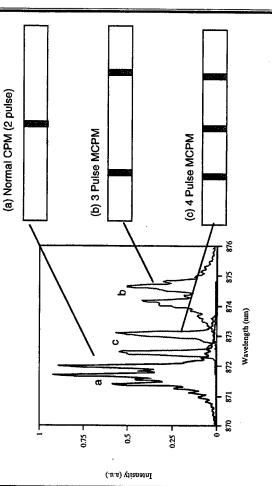
The idea of the CPM laser can be extended to multiple coliding pulse lasers. By introducing more Saturable absorbers the laser can be made to operate with more pulses circulating in the laser



three section labelled a,b, c if reversed biased operate as The illustration shows the electrical layout of the chip the saturable absorbers if forward biased operate as gain

Four section MCPM laser **Optical Spectra**

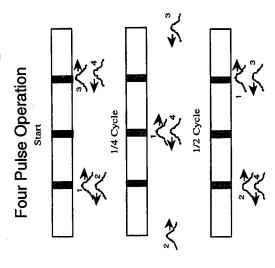
(MCPM- Multiple Colliding Pulse Modelocking)



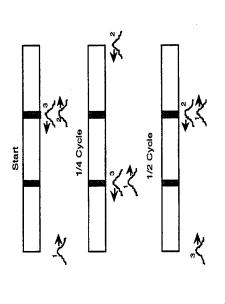
The spectra show the effect of the different biasing conditions

- (a) The normal CPM operation with one saturable absorber in the middle at two pulses circulating. The spectrum has the normal mode spacing doubled
- (b)Three pulse MCPM operation. The mode spacing increases by a factor of 3
- (c)Four pulse MCPM operation. The mode spacing increases by a factor of 4.

MCPM Laser Operation



Three Pulse Operation



MCPM Rule: Avoid pulse collisions in gain sections

3 July 1996

TeraHertz 12 4 sectioned laser operation

Spontaneous emission

Single mode operation

Multimode operation

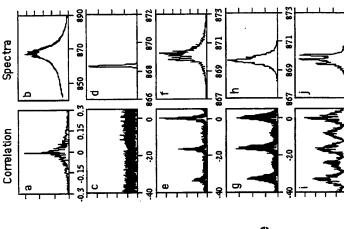
Modelocked single pulse (55 GHz rep rate)

CPM (2 pulse) operation (110 GHz rep rate)

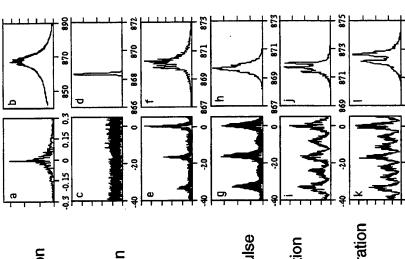
MCPM (3 pulse) operation (165 GHz rep rate)

MCPM 4 pulse operation (220 GHz rep rate)

resonator (375 GHz rep rate)



MCPM 4 pulse shorter



Wavelength (nm) 874 876 Delay (ps)

8

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modelocked lasers section Conclusion to monolithic

monolithic modelocked semiconductor lasers with high * Employing simple laser diode fabrication techniques epetition pulses rates can be made

possibility of very low cost sources of high repetition rate 'Monolithic mode-locked semiconductor lasers offer the ultrashort pulses which are compact, reliable, robust efficient and can be mass-produced. *Possible applications include sources for conversion to microwaves source for electro-optic sampling of MIMICs

Introduction to RTD section

* Since the discovery that the RTD has sufficient negative concentrated on entirely electronic devices for microwave differential resistance for practical devices most work has applications.

optoelectronic modulation at microwave frequencies from the electric field associated with the RTD by embedding the * We discuss a simple direct integration scheme to achieve RTD directly in an optical waveguide.

distribution and the optical characteristics of the guide are waveguide is strongly dependent on the bias voltage, this allows small changes in the biasing voltage close to resonance to give a large change in the electric field With a RTD the electric field distribution across the ield dependent via the Franz-Kelydsh effect.

current-voltage characteristics of the guide which can enable the electric field across the waveguide to * The RTD can introduce instabilities into the self-oscillate at microwave frequencies.

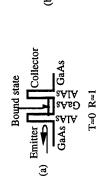
microwave/optical interface by removing the need for large drive voltages to produce a significant level of modulation. *The device has considerable potential as a

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A

Resonant Tunneling diode operation





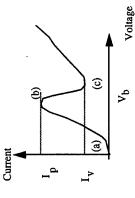


T≈1 R≈0

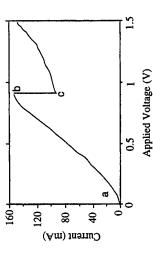
I≈1 R=0

The above diagrams show the lowest energy of the conduction band in a GaAs/AIAs semiconductor heterstructure under various biasing conditions.

The diagram below is a generic I-V curve corresponding to the above description.



Franz-Keldysh effect with a RTI



For our devices, in the off- resonance condition corresponding to c in the above diagram the voltage drop, Vd, across the depletion layer is given by:-

$$I_b R_s = V_b = V_c = I_c R_s + V_d$$
 $V_d = V_b \left(1 - \frac{I_c}{I_b} \right) = 0.34 \text{ V}$

The depletion layer thickness in our devices is

$$D = \left(W^2 + 2\frac{\mathcal{E}}{eN_d}V_d\right)^{\frac{1}{2}} \quad 0.157 \, \mu \text{m}$$

If we assume a uniform field then we have

$$E = \frac{V_d}{D}$$
 2.20 MV.m-1

The Franz-Kelydsh band-edge shift is given by:-

$$S = -\left(\frac{(eE\hbar)^2}{2m^*}\right)^{1/3}$$

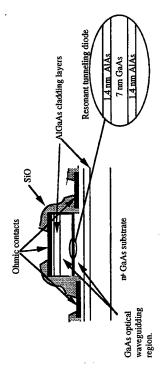
From this the calculated shift in the band-edge should be 9 nm; the observed shift is 14 nm.

We must use waveguide geometry because of thin depletion layer.

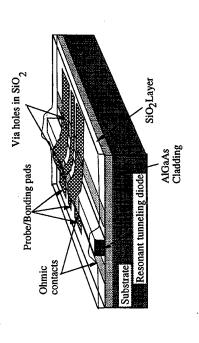
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RTD Optical Waveguide device

Device Cross-Section

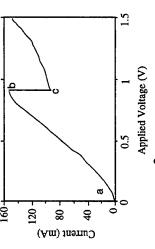


Chip layout

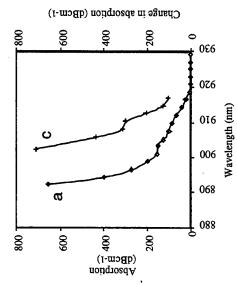


Franz-Keldysh effect in RTI Optical Waveguide device

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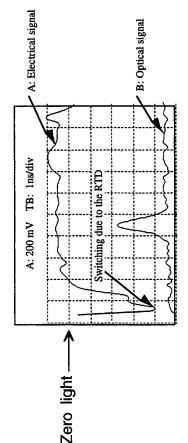
IV curve for a 800 µm² RTD electroabsoprtion modulator.



- Change in Absorption induced by the RTD switching.
- Measured bandedge

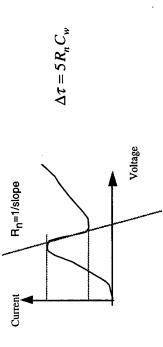
The letters a and c correspond to the letters on the I-V curve.

Resonant Tunneling diode optical modulation results



the light is 900 nm. The optical signal is inverted and the change in absorption is characterised of 3 dB modulation in a 100µm long active region. The delay between the optical and electrical pulse is Electro-absorption from a 2 ns electrical pulse. The wavelength of due to propagation delay in free space and electrical cable.

Resonant Tunneling Diode optical nodulation limits to speed

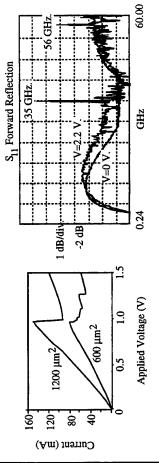


for our device the switching time ~7.5ps, bandwidth ~ 130GHz.

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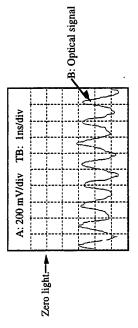
Self - oscillation of the RTI modulator and applied modulation



There is some evidence of self osccilation in I-V curves which is confirmed by S parameter measurements.

We have not yet measured optical modulation in a self oscillating device.

Some direct modulation experiments have been carried out:-



Optical response to a 0.2 V, 900 MHz applied electrical

Conclusions

*Monolithic modelocking of a semconductor laser at repetition rates of up to 375 GHz has been described.

*The four sectioned MCPM laser is programmable and can operate in 1,2,3, or 4 pulse mode.

'An RTD optoelectronic modulator has been described capable of ~10dB of modulation in a 100μm device. The device has gain at microwave frequencies and it can operate with low drive powers.

*There some evidence of self oscillation operation.

Future Work

Synchronisation

monolithic modelocked device and the RTD device to optical We are investigating the synchronisation of both the andelectrical external signals.

*Detectors/ Converters

There is now a requirement for devices which can efficiently convert optical signal to microwave signals. These are now being investigated by several groups using materials with reduced carrier lifetimes either low temperature grown material or material damaged by ion bombardment.

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Monolithic Modelocking

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Measurements of reverse and forward bias absorption and gain spectra in semiconductor laser material" S. D. McDougall and C. N. Ironside Electronics Letts 31 2179-2181 1995. "Multiple colliding pulse operation of a semiconductor laser" J. F. Martins-Filho and C. N. Ironside Appl. Phys. Lett. 65 1894-1896 1994

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RTD Modulator

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